

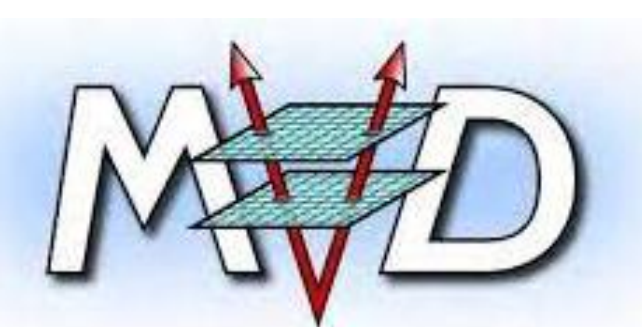
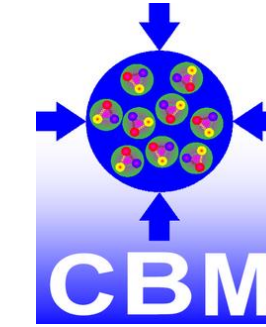


MVD goes China

谢谢





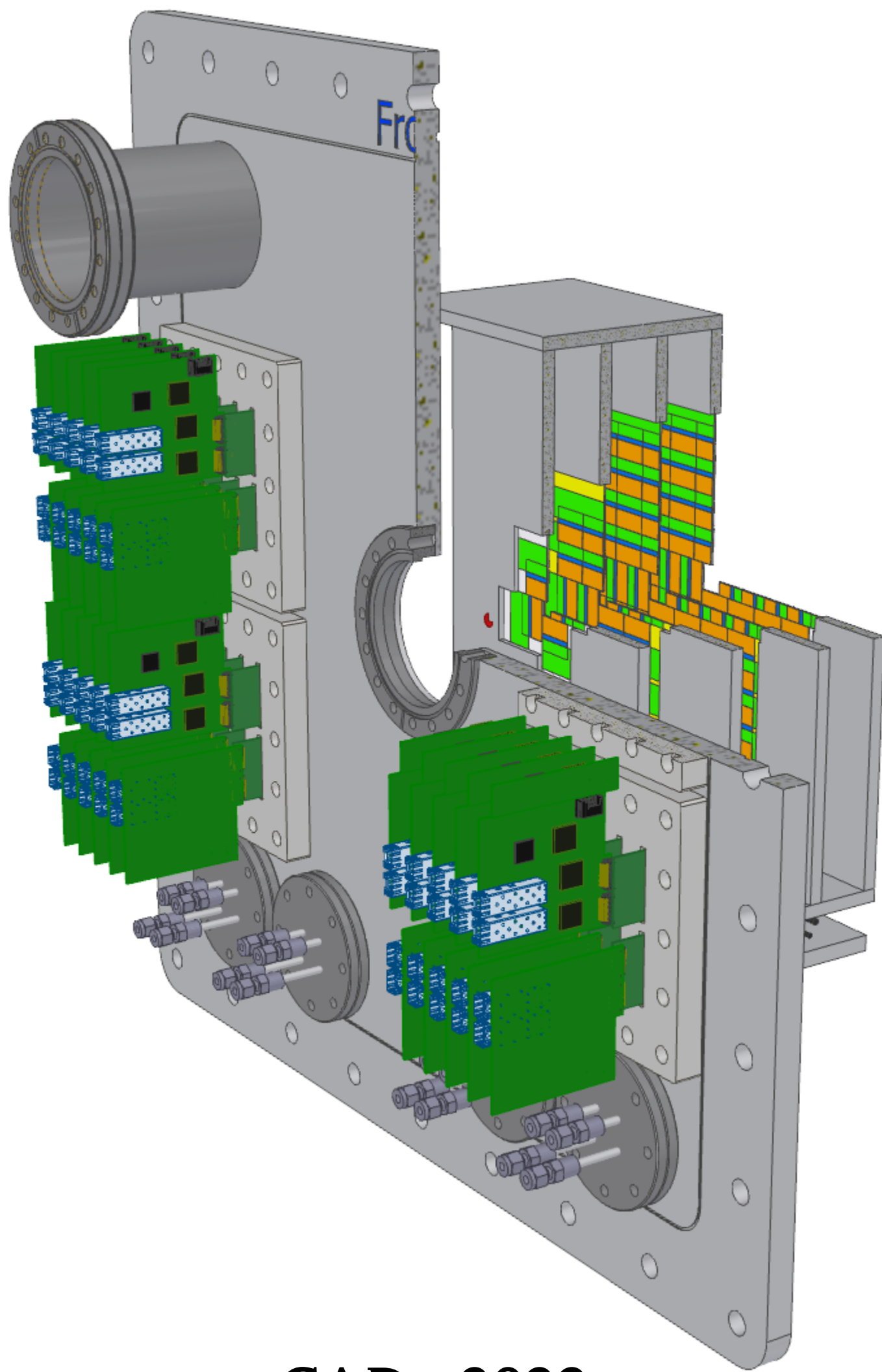


# Sensor and Detector Integration

## The MVD on the Road to Production

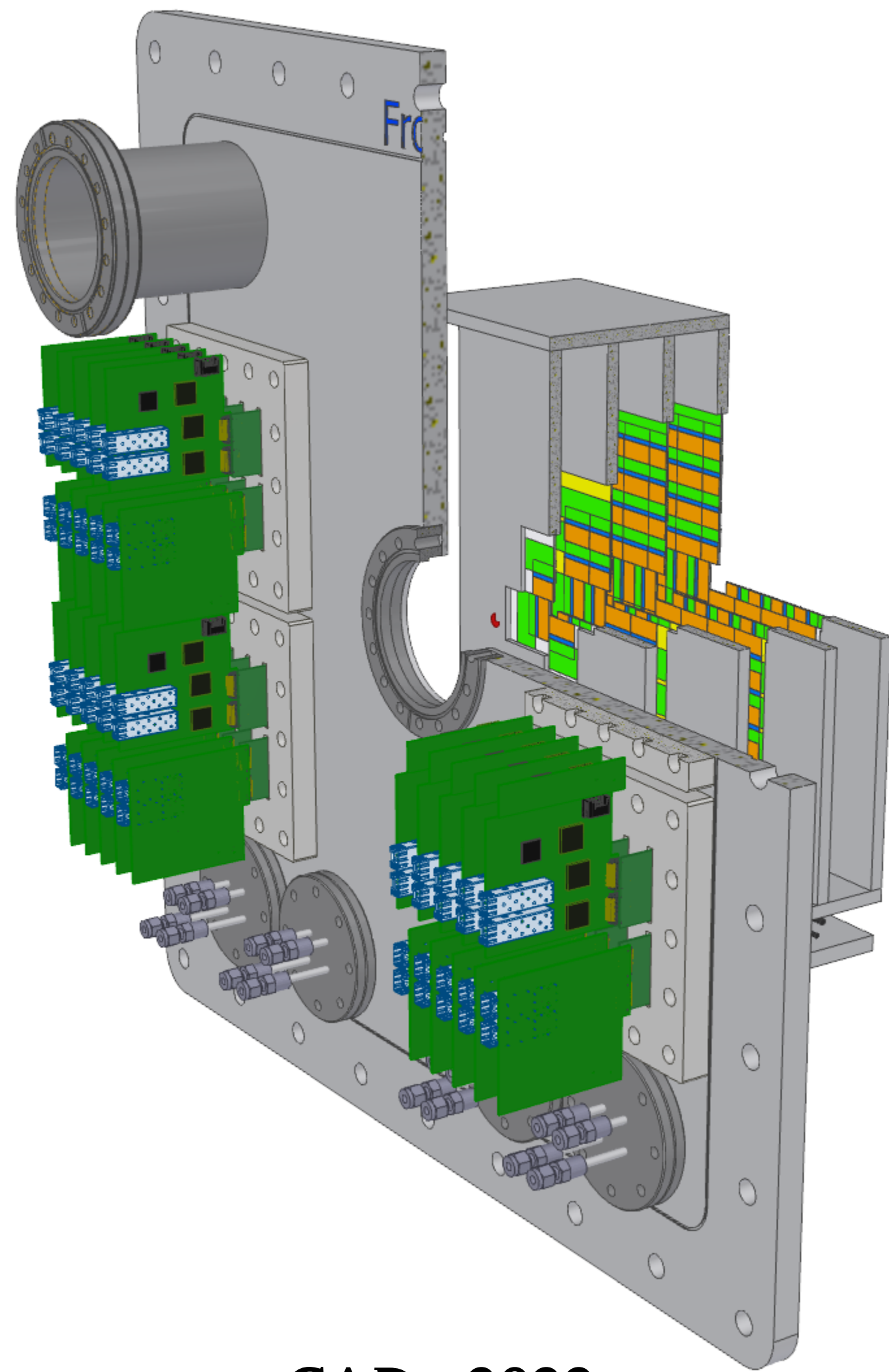
Franz A. Matejcek with Highlights from the CBM MVD Team

46<sup>th</sup> CBM Collaboration Meeting, Lanzhou, 24.10.2025

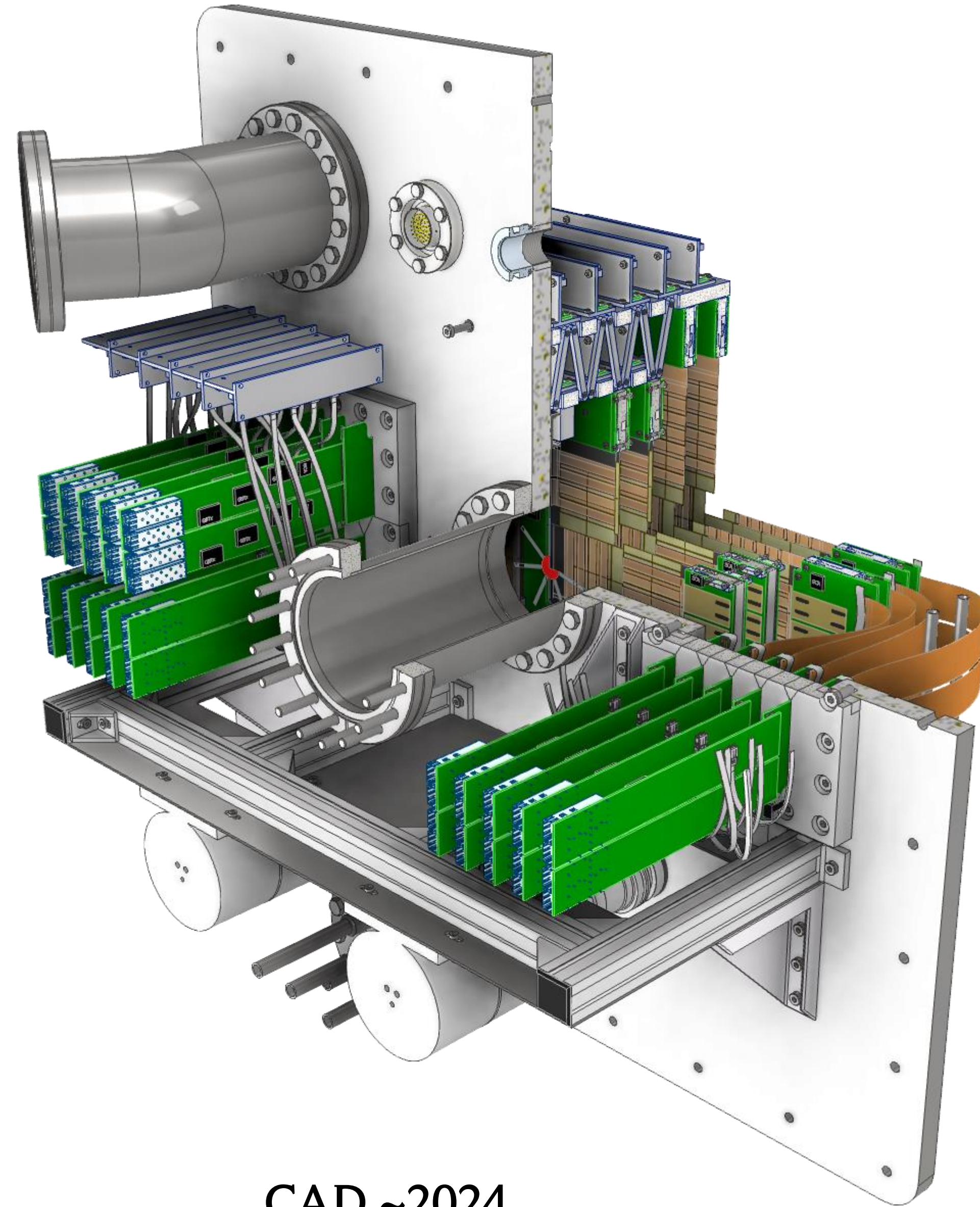


CAD ~2022



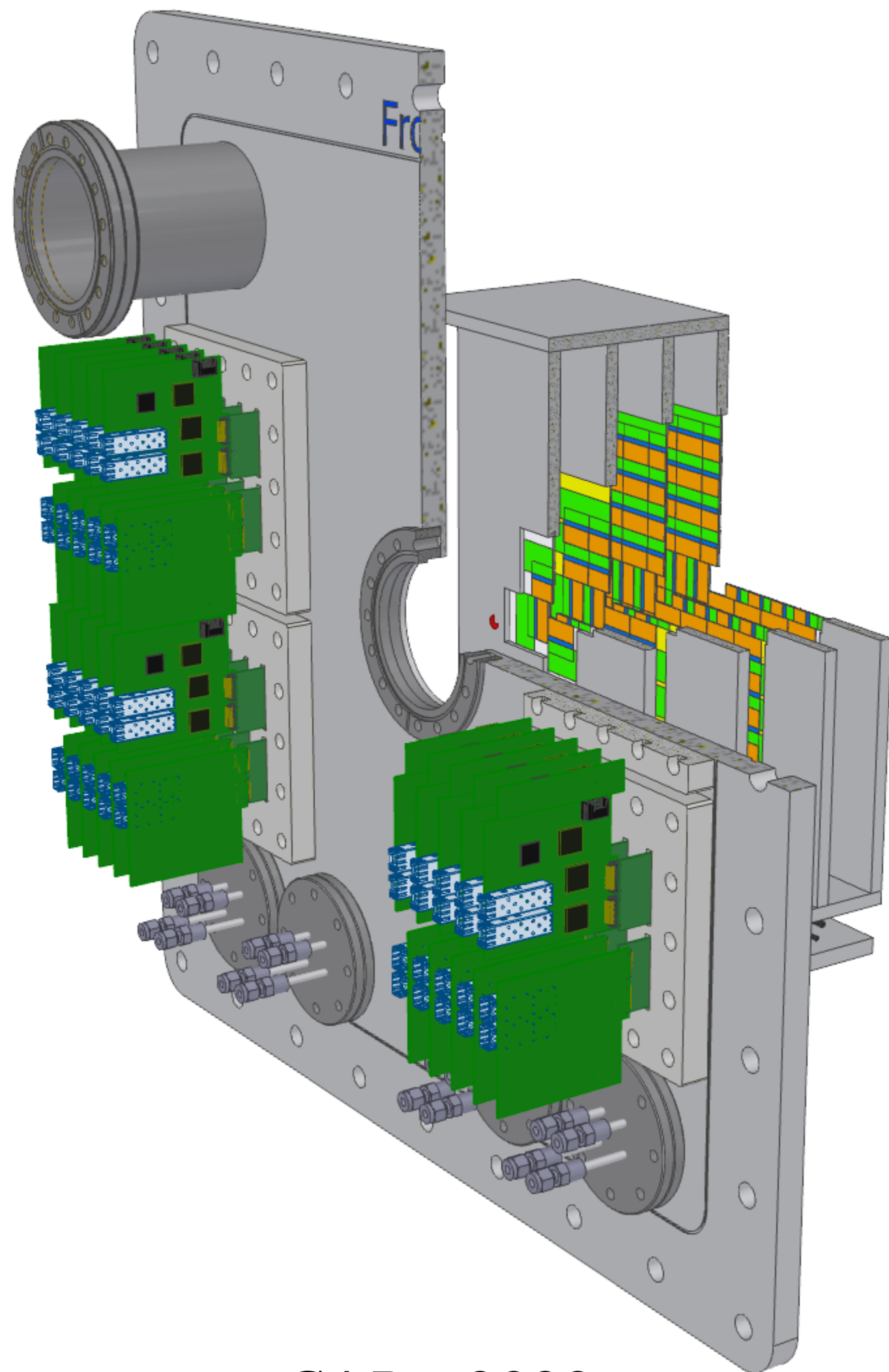


CAD ~2022

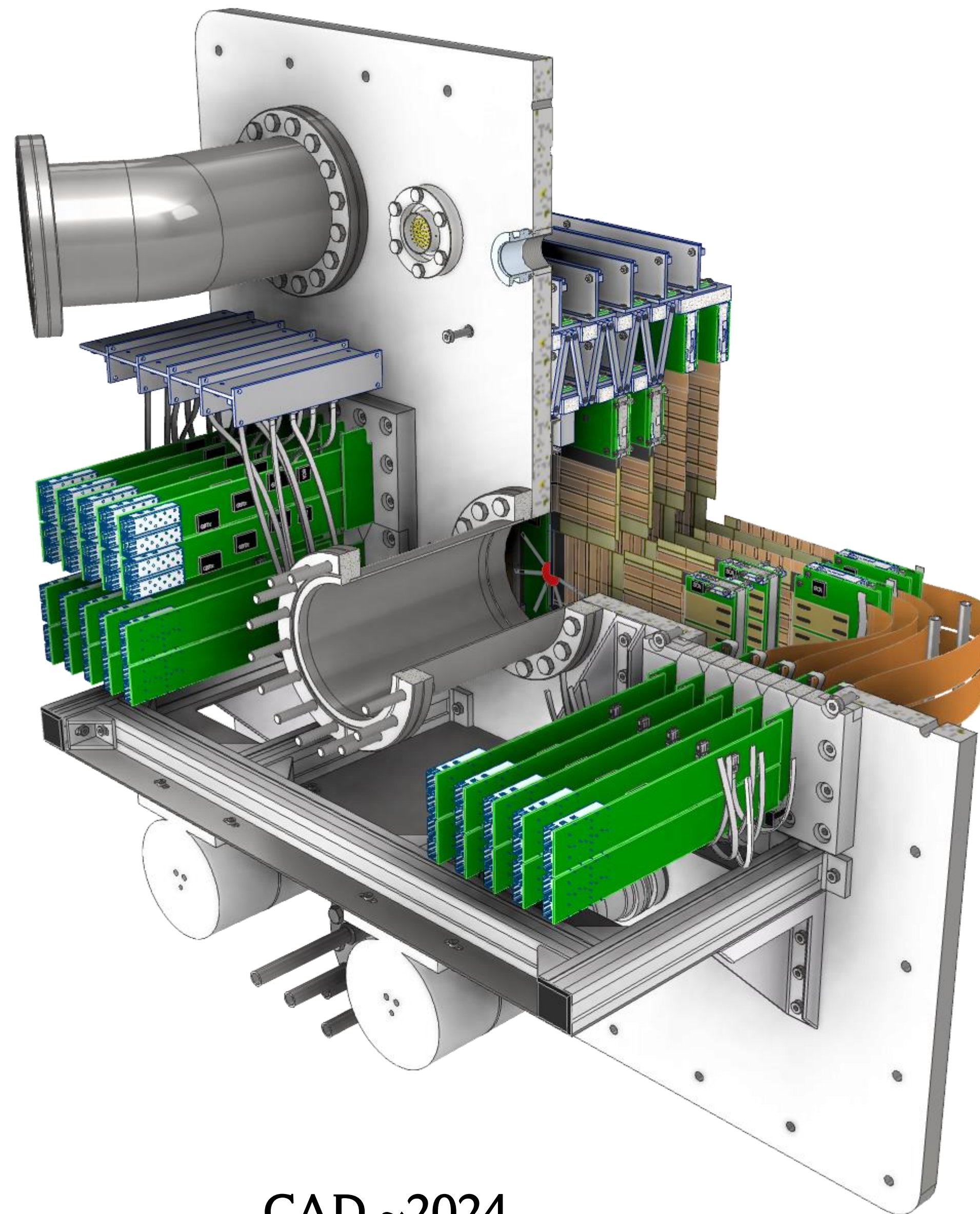


CAD ~2024

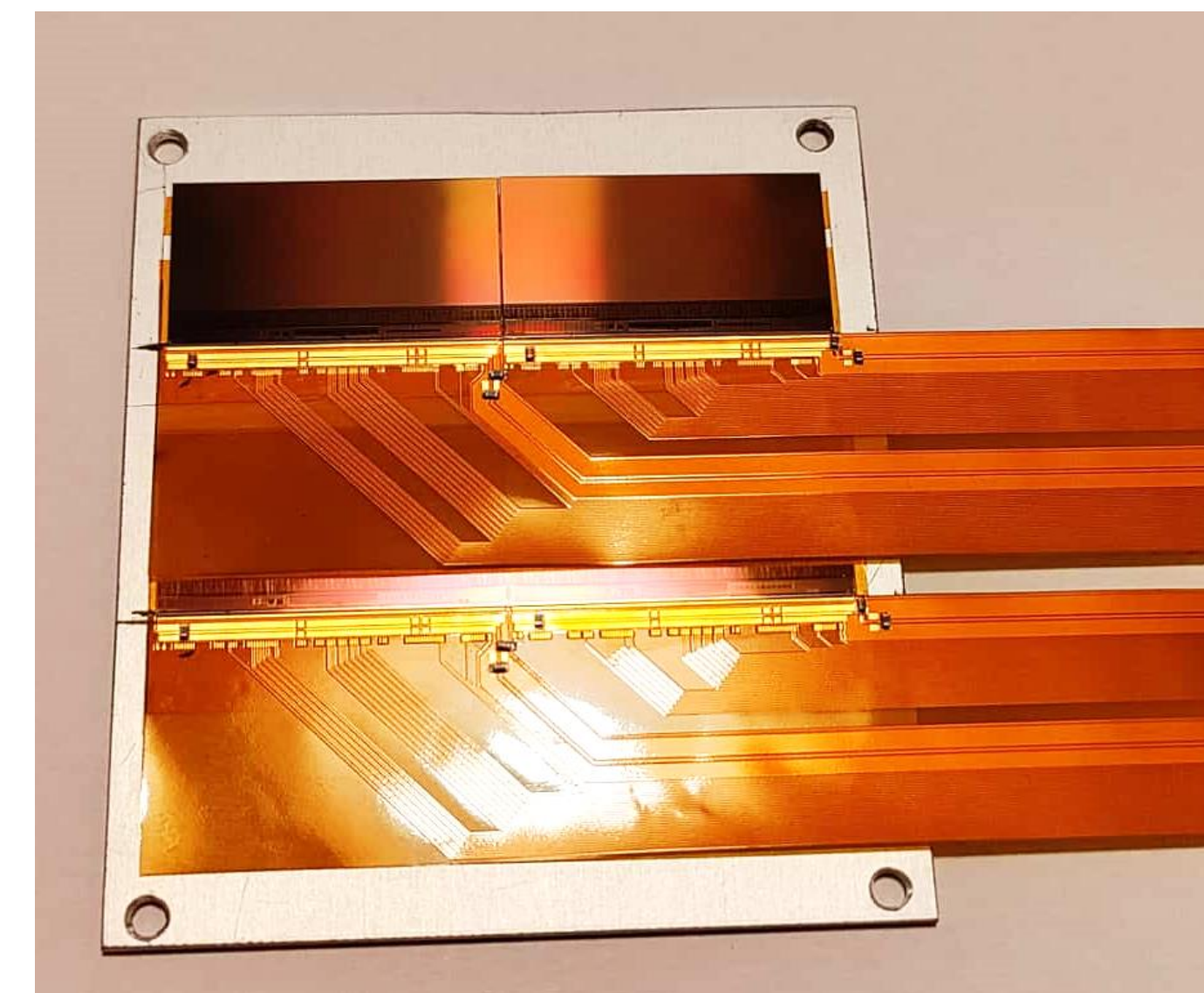




CAD ~2022

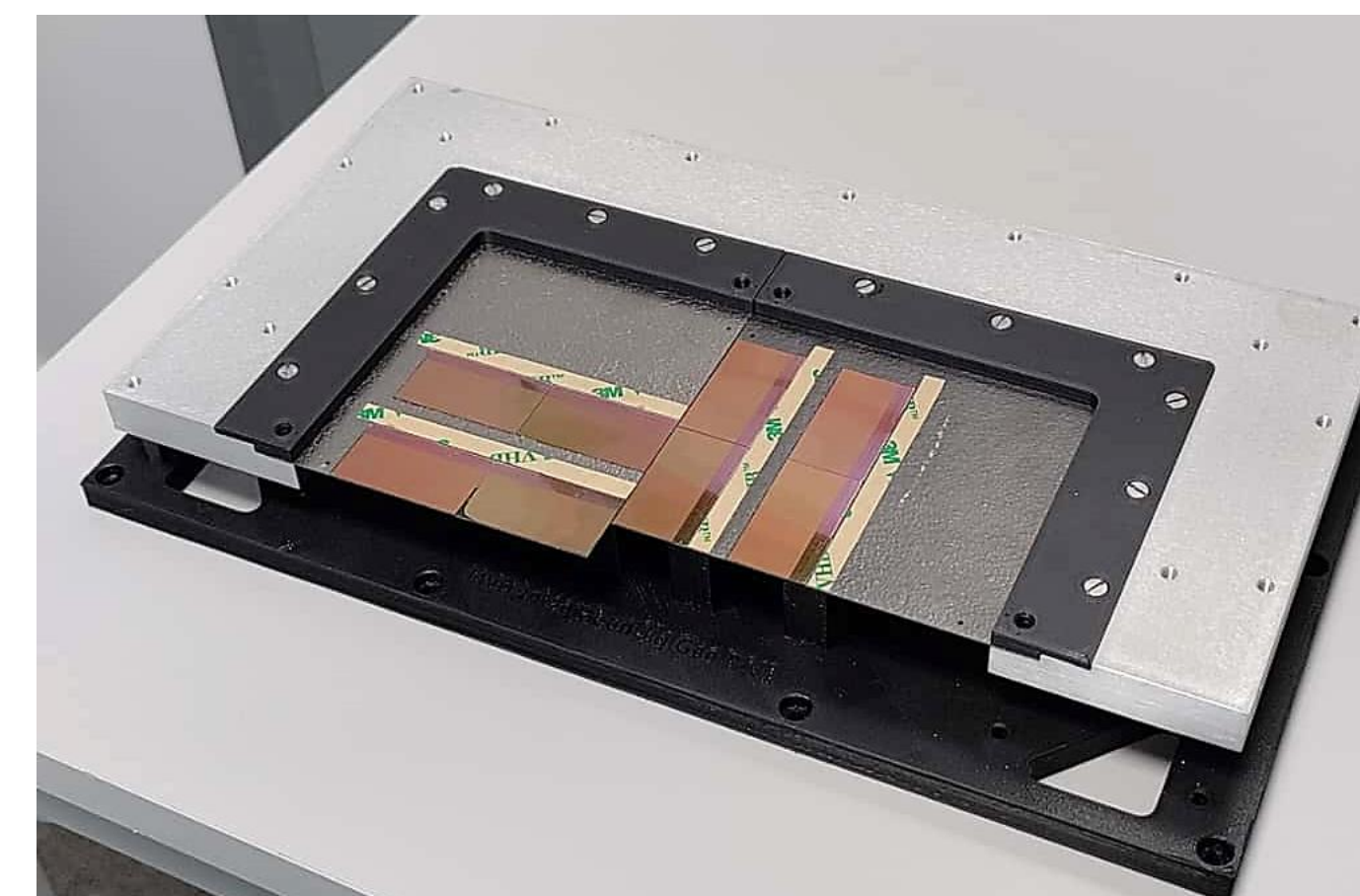


CAD ~2024

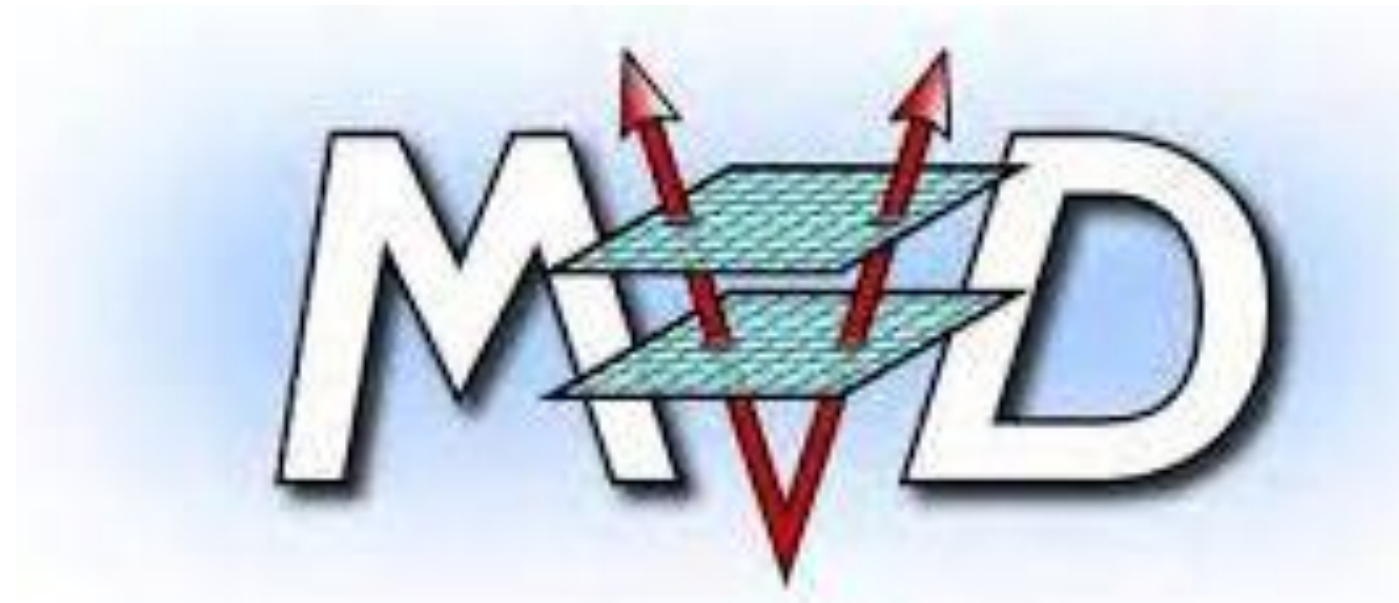


MIMOSIS-2.1 with MVD FPC

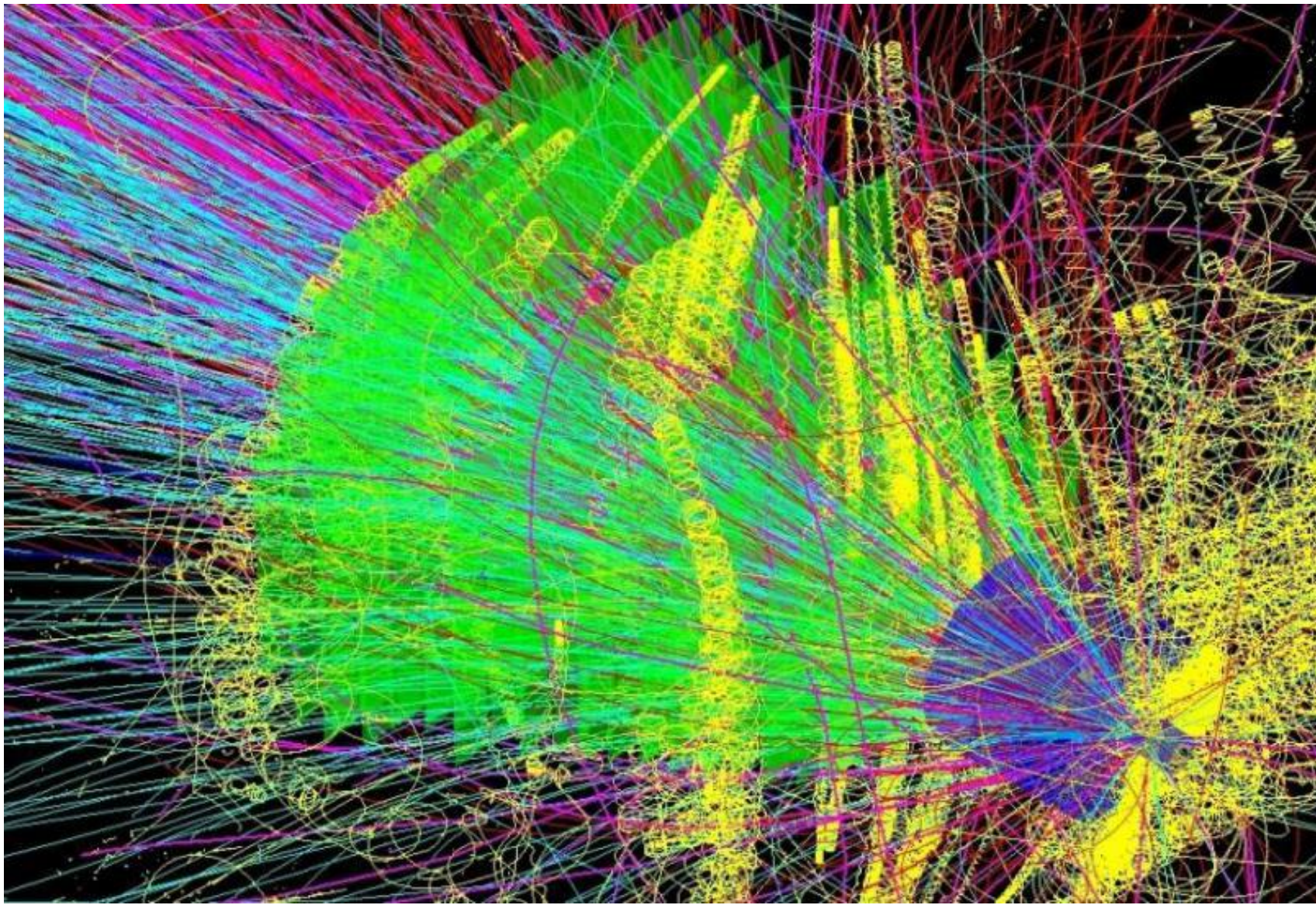
MIMOSIS-2 on TPG



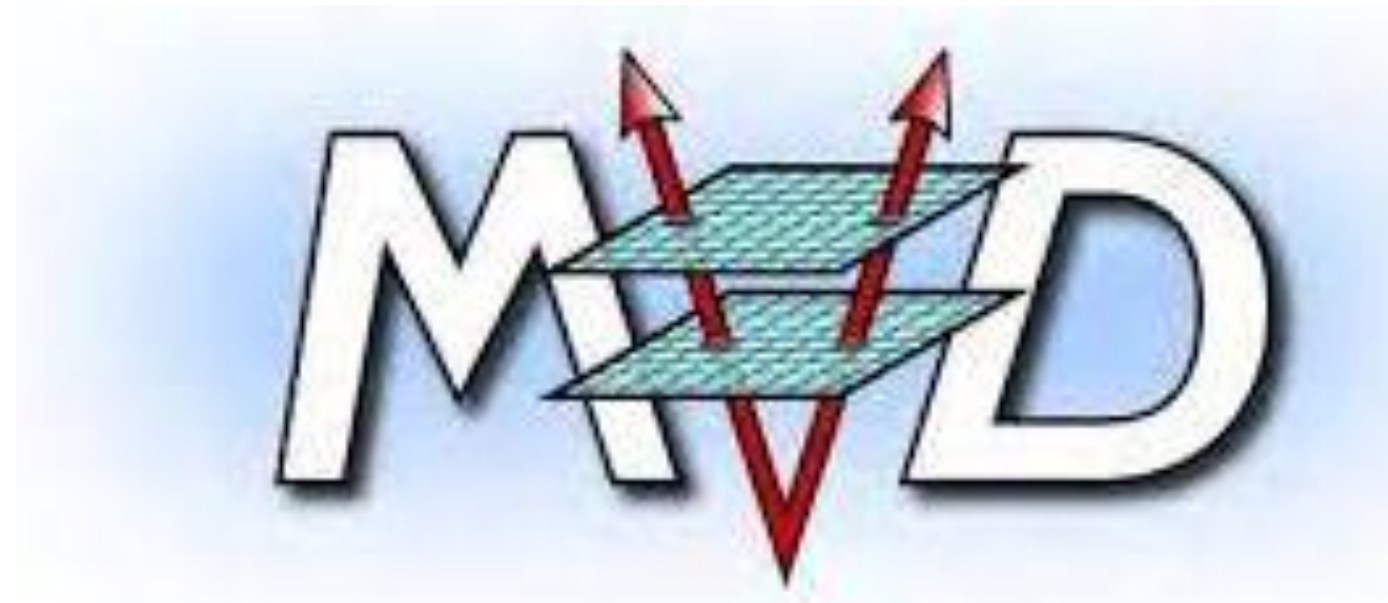




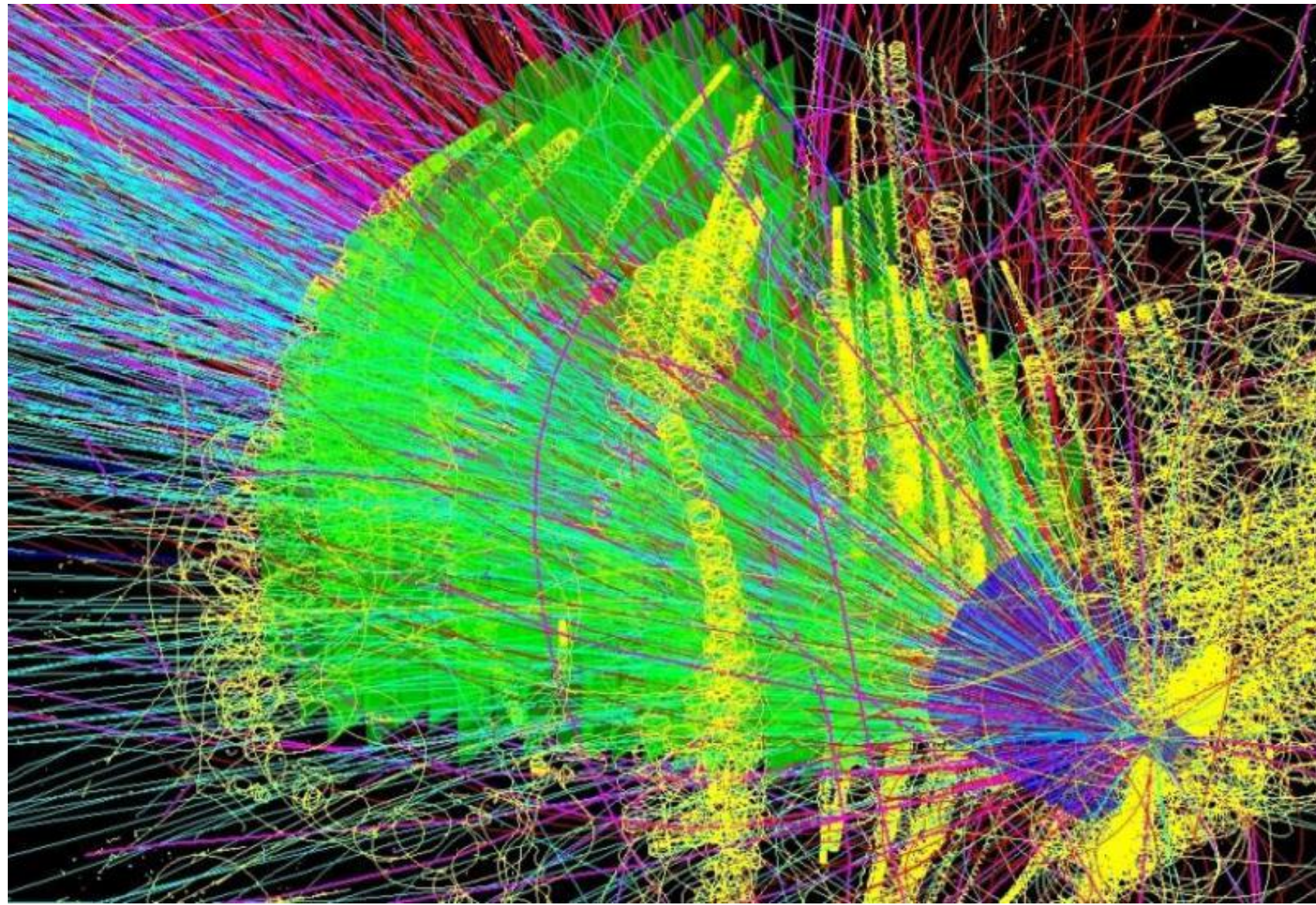




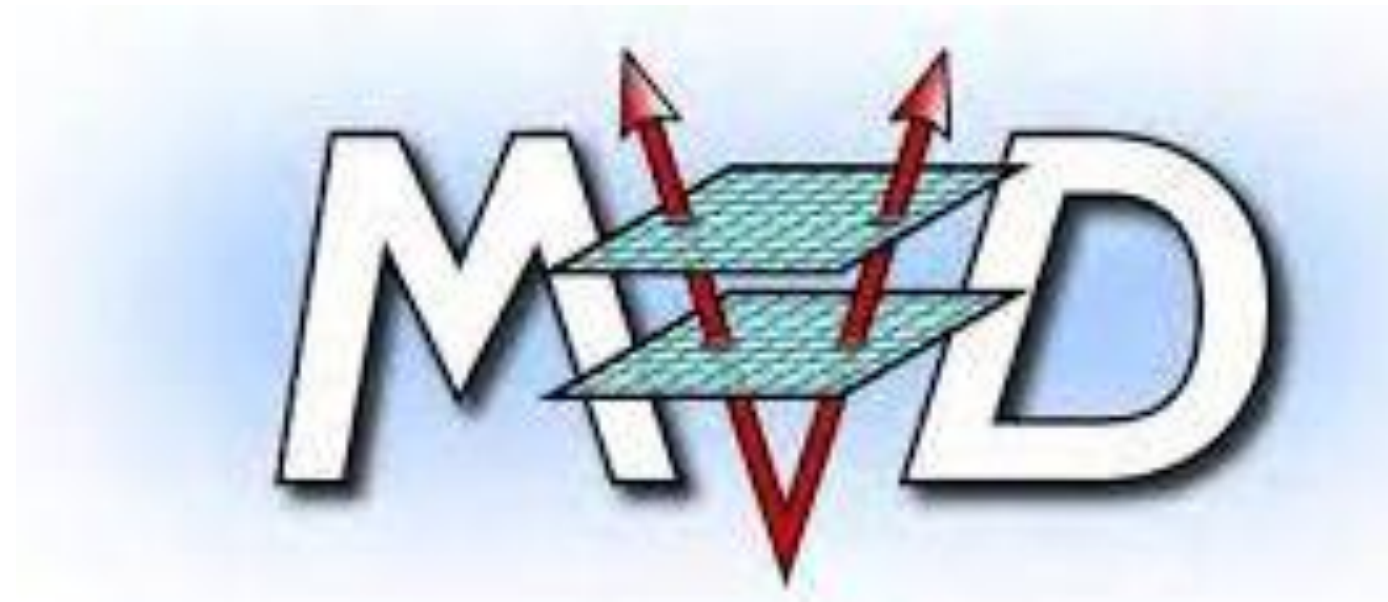
High-precision tracking & vertexing  
in closest proximity to the target



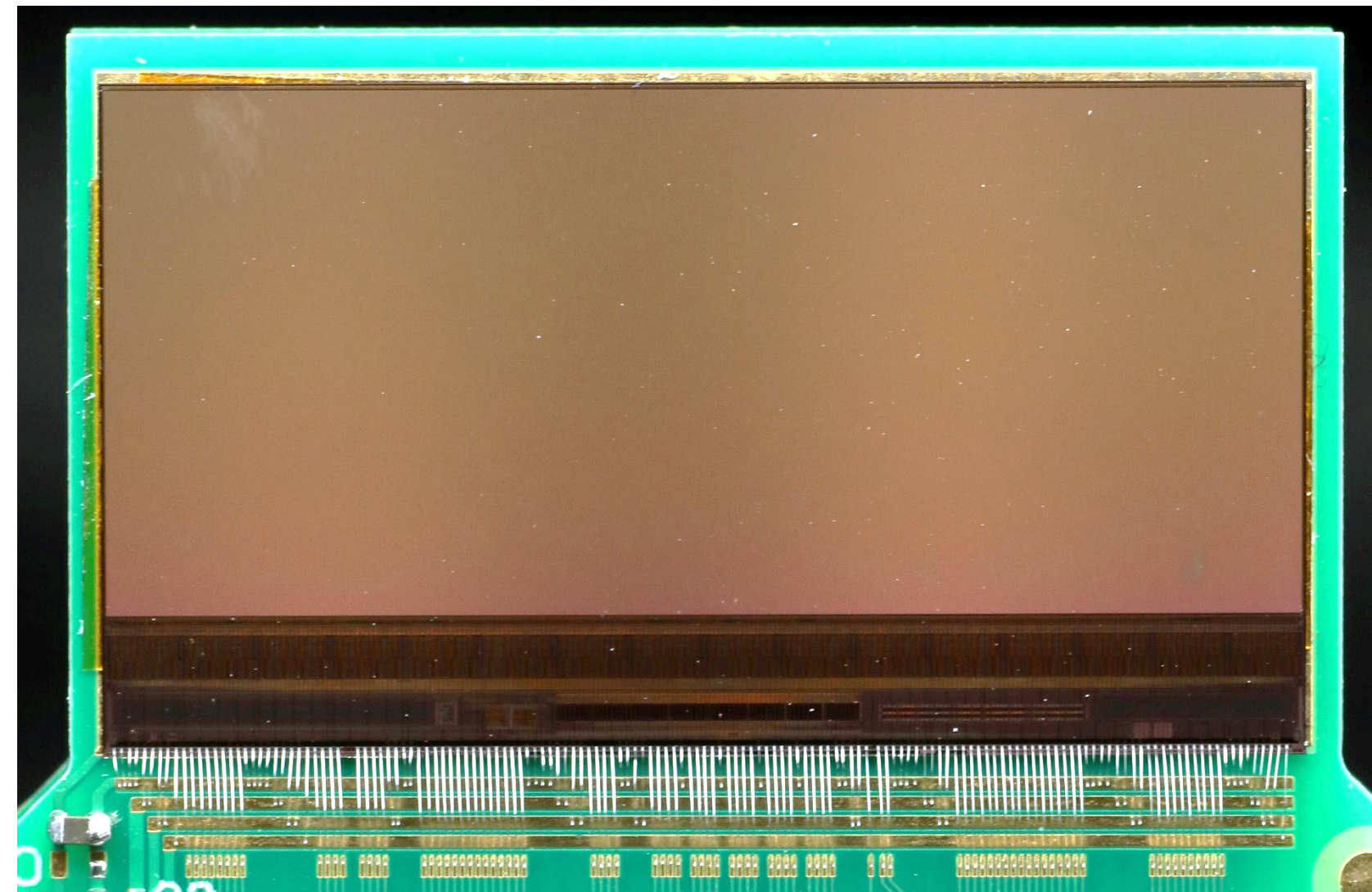




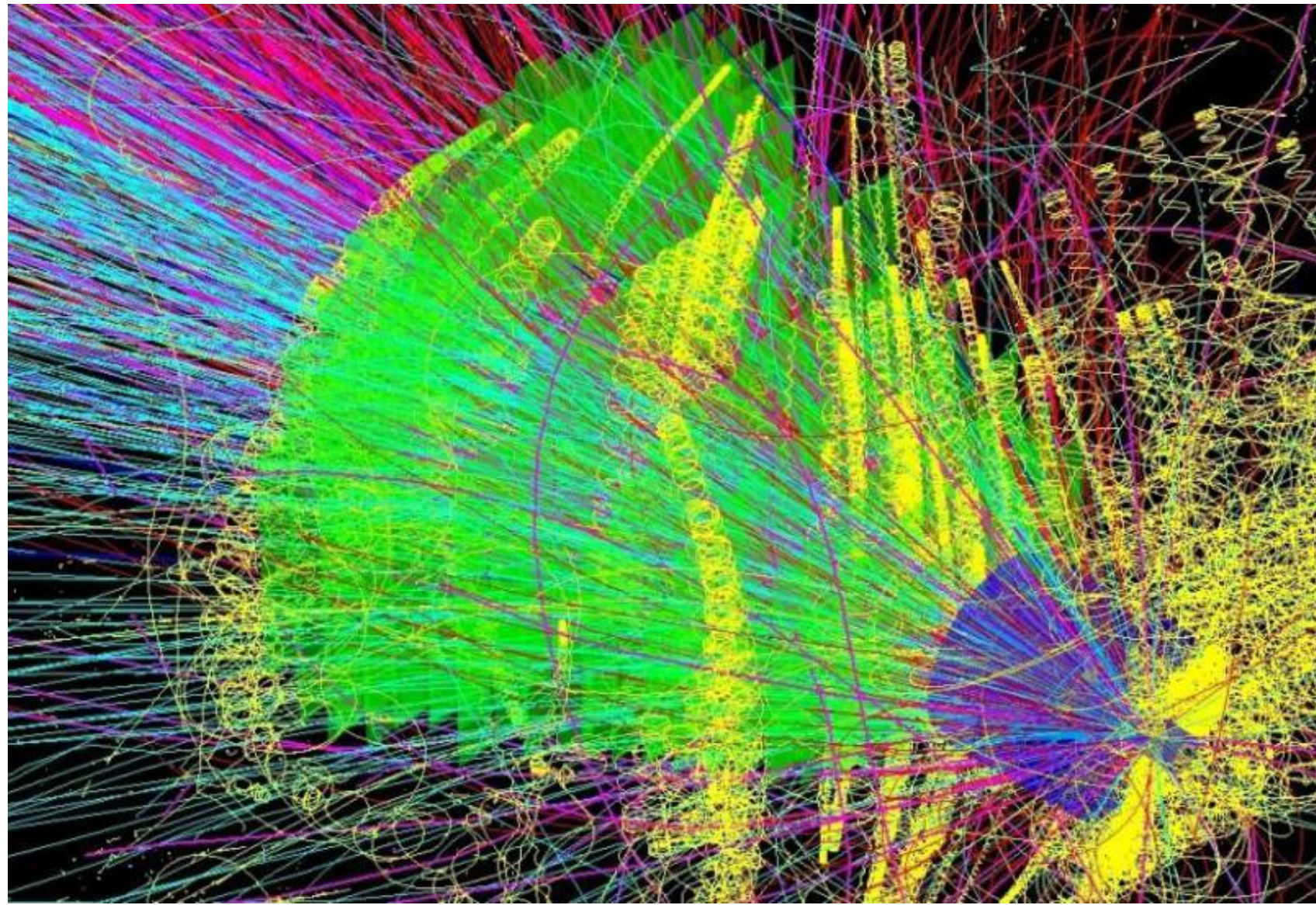
High-precision tracking & vertexing  
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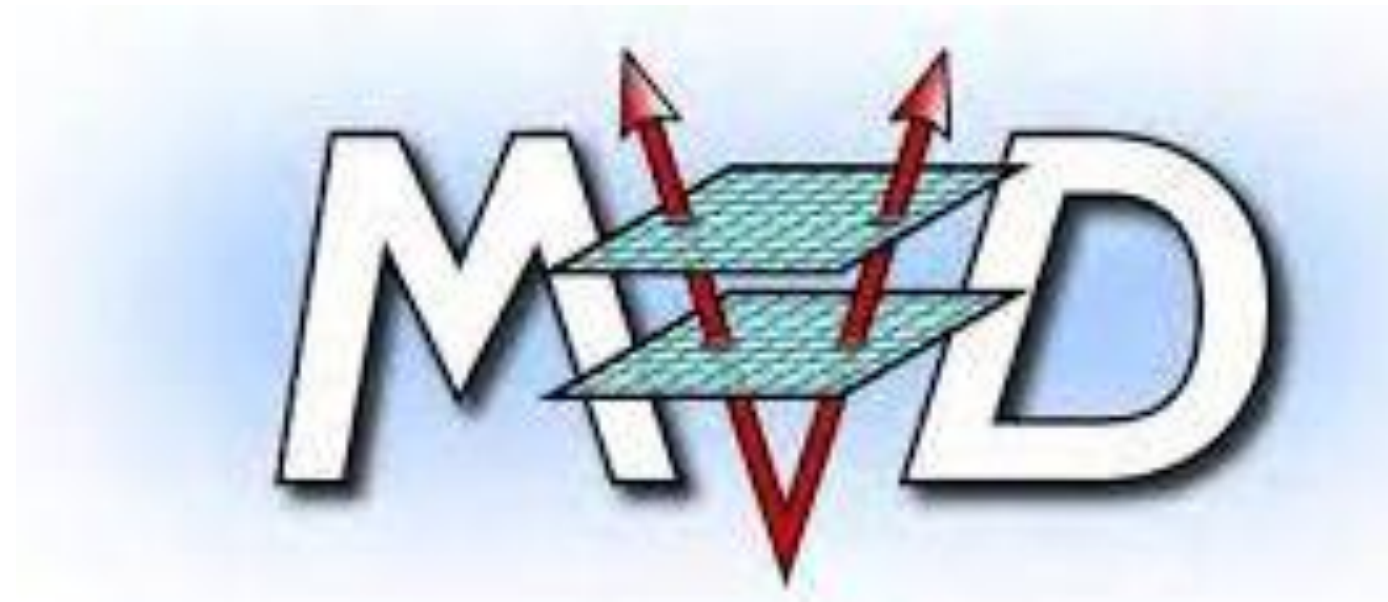
300 CMOS monolithic active  
pixel sensors (MIMOSIS)



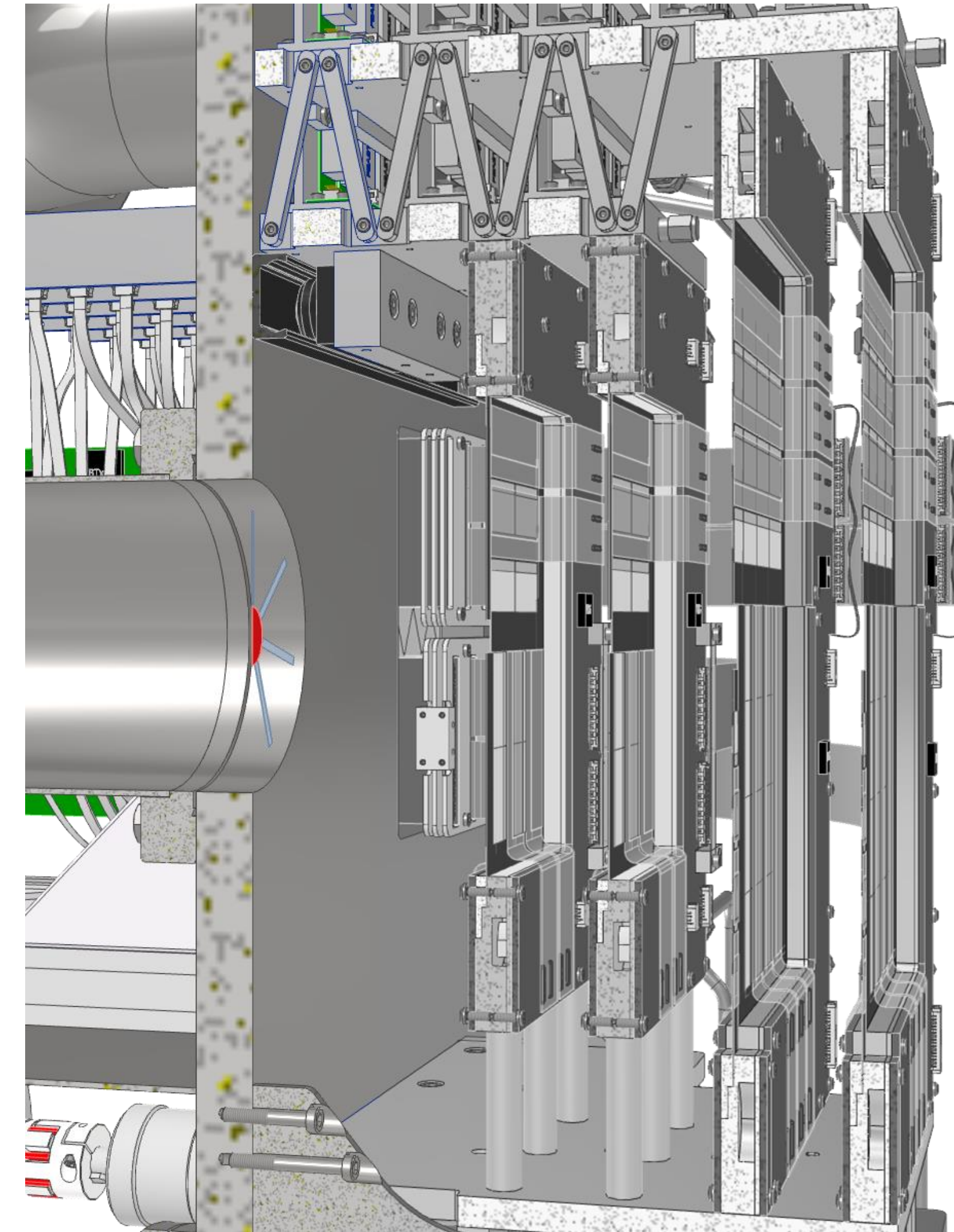
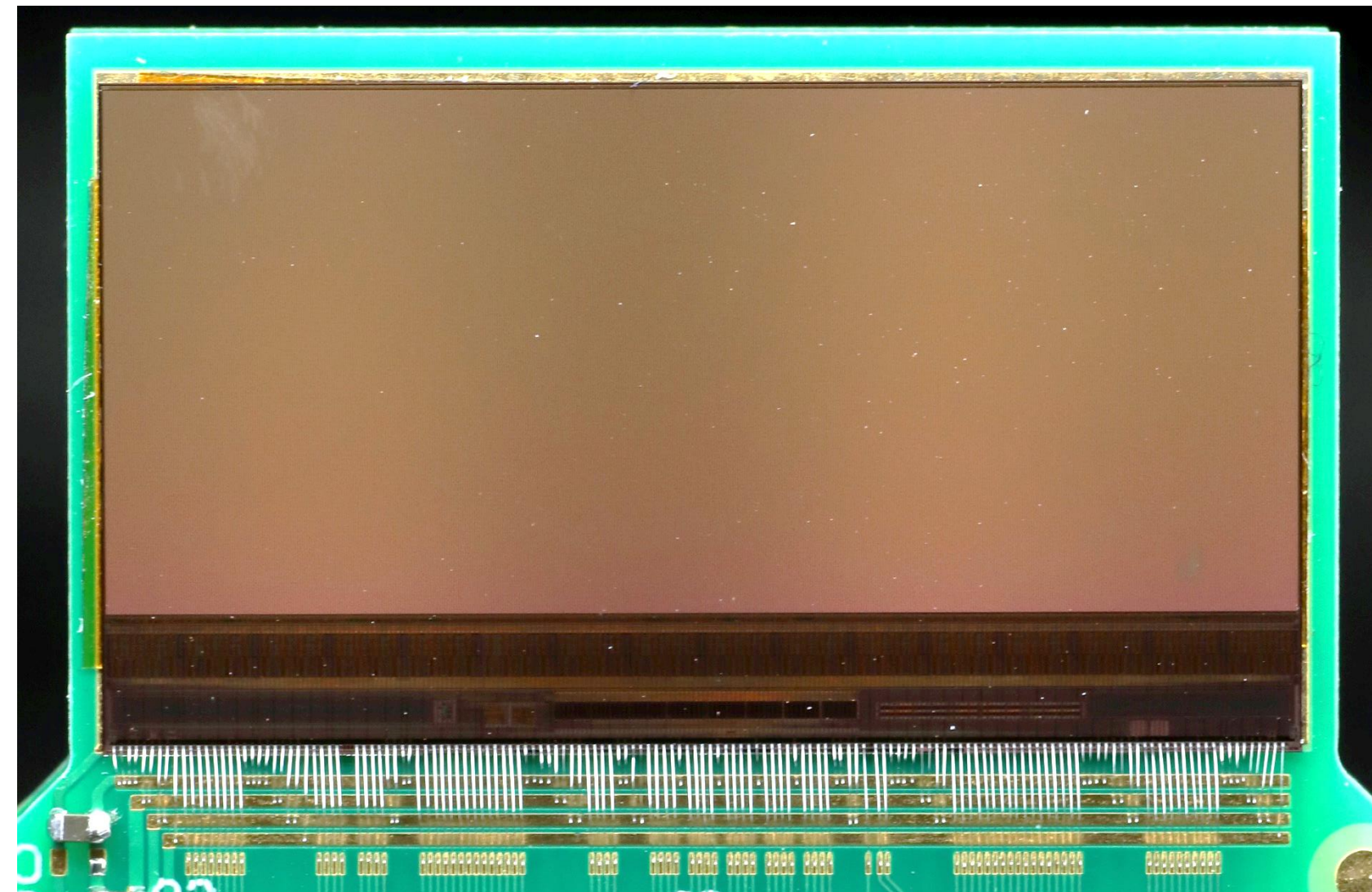




High-precision tracking & vertexing  
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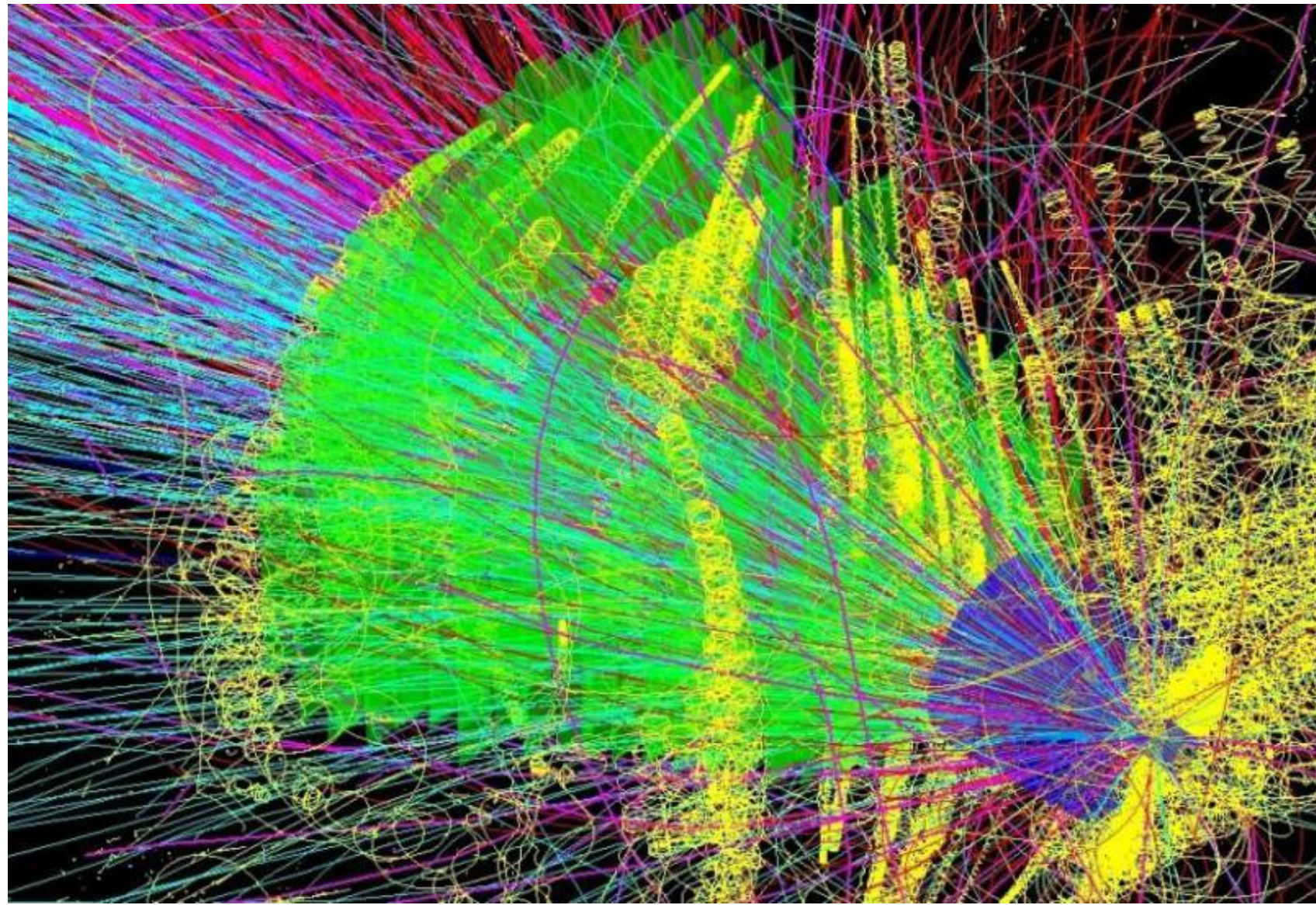


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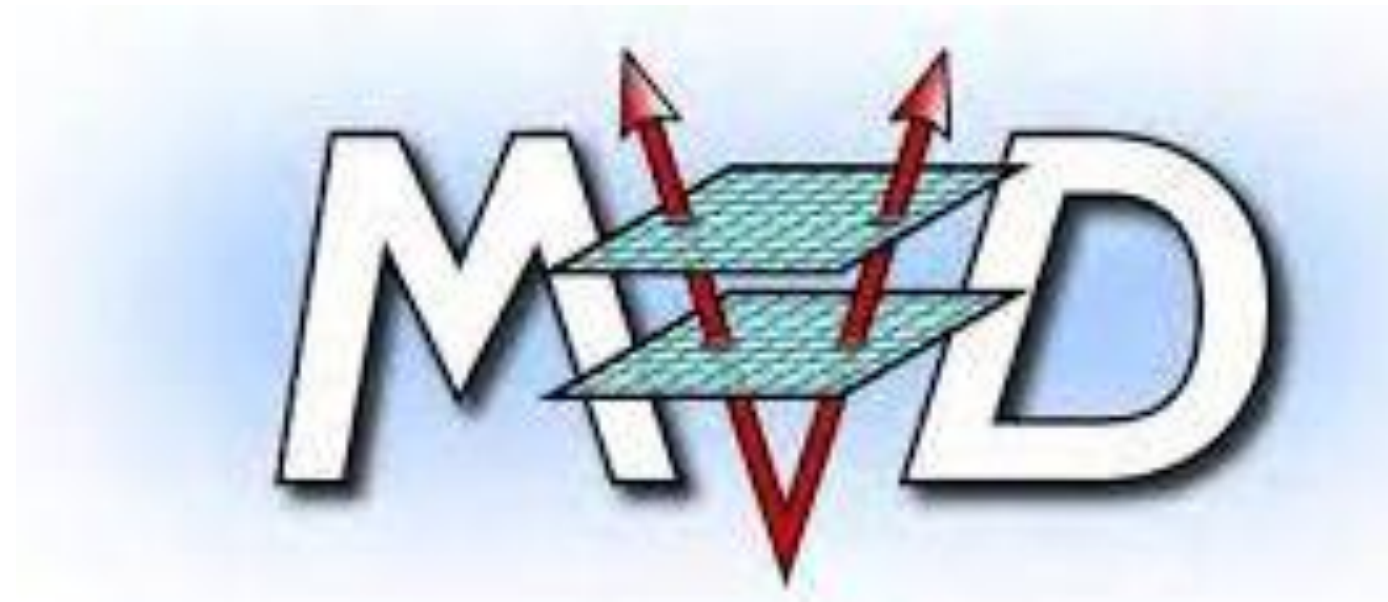


2+2 ultra-low material budget planar  
detector stations in vacuum

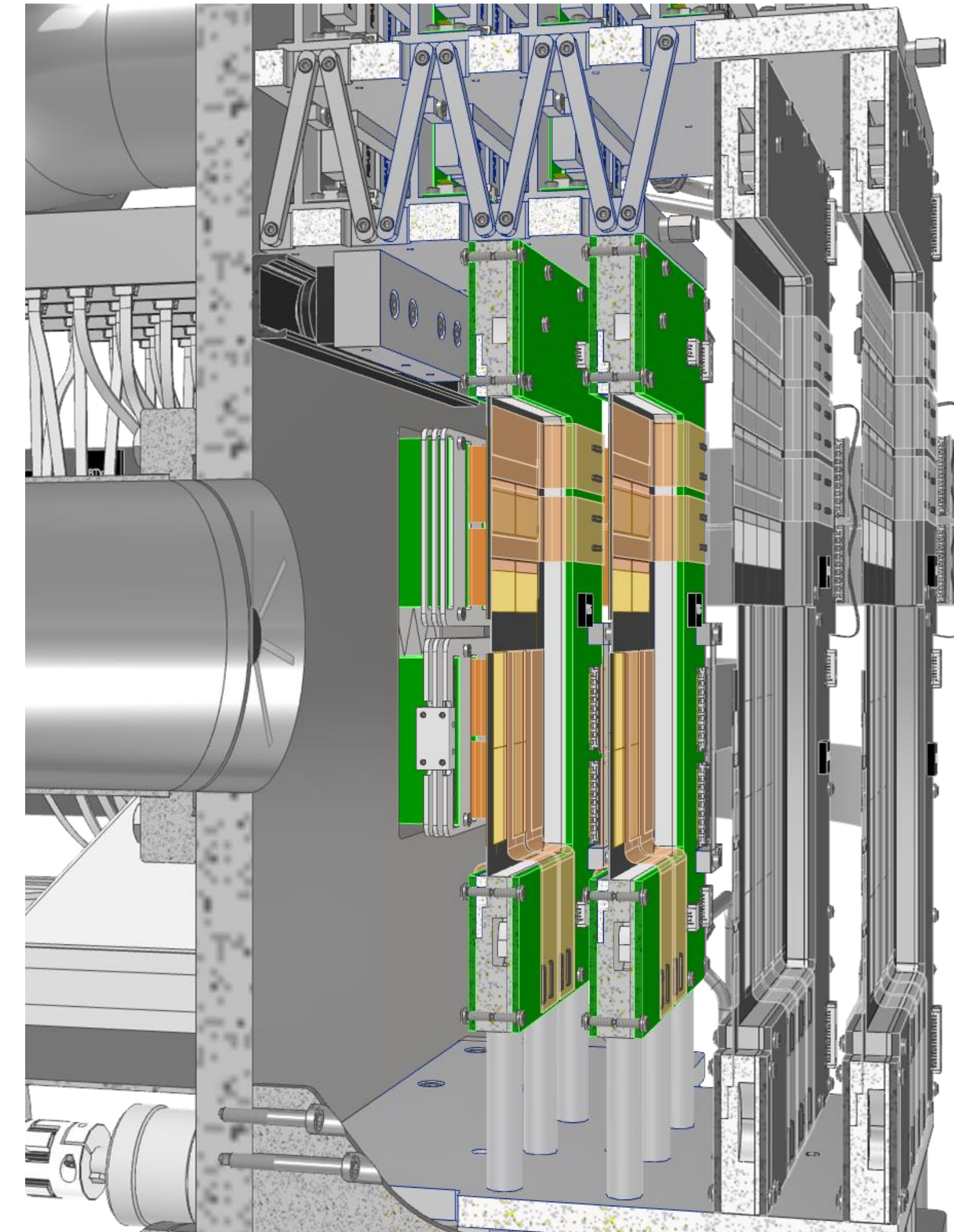
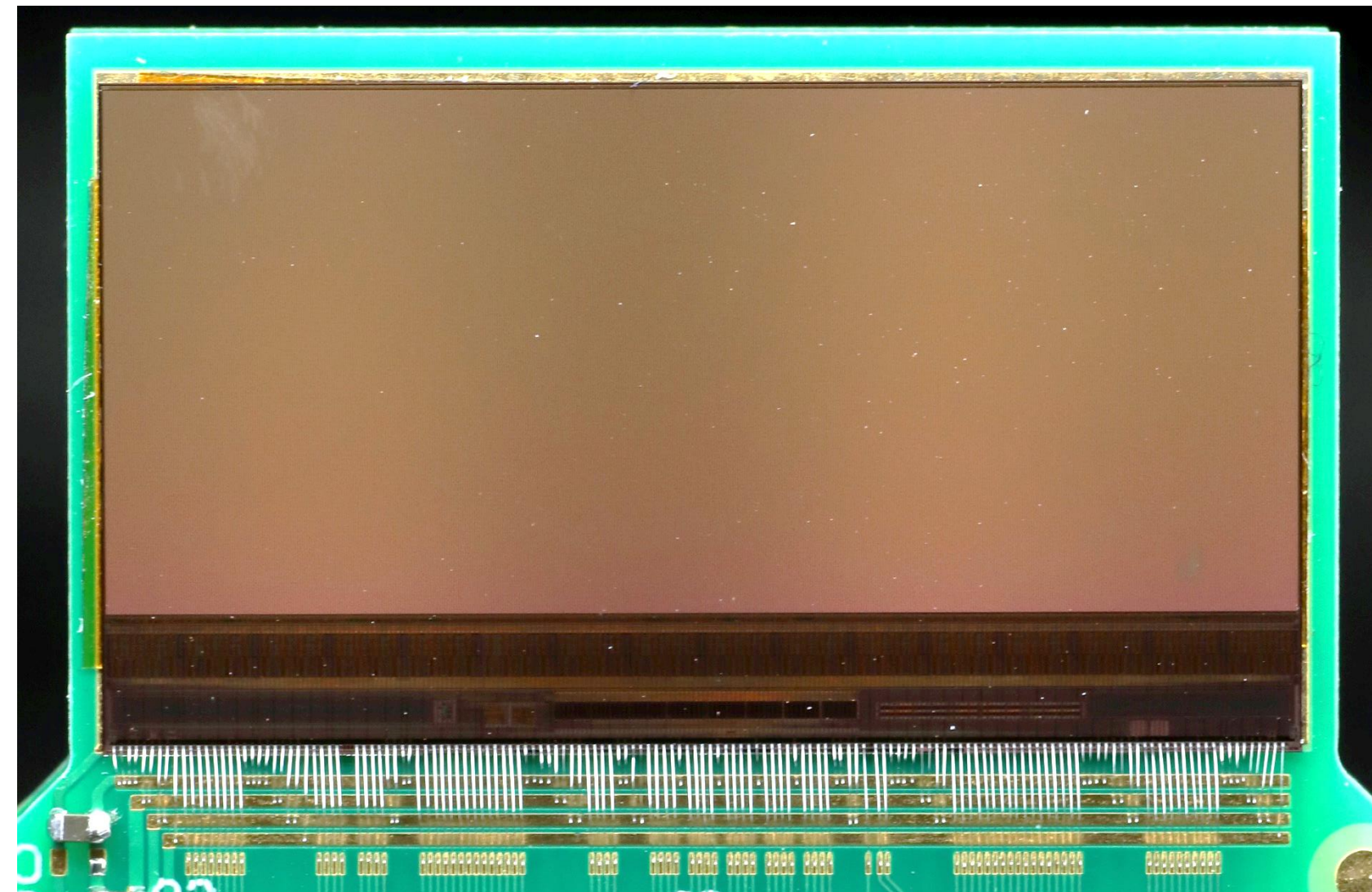




High-precision tracking & vertexing  
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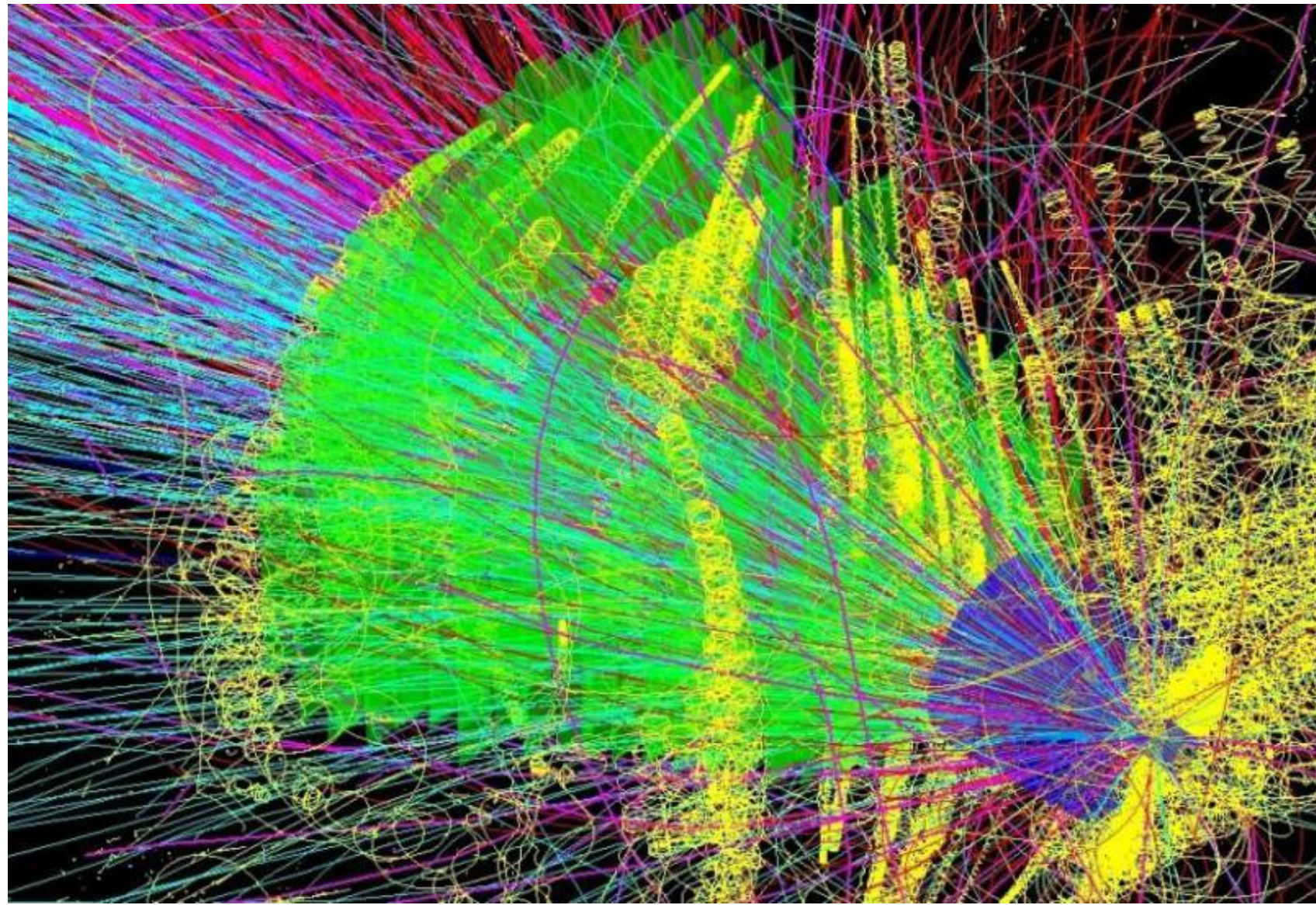


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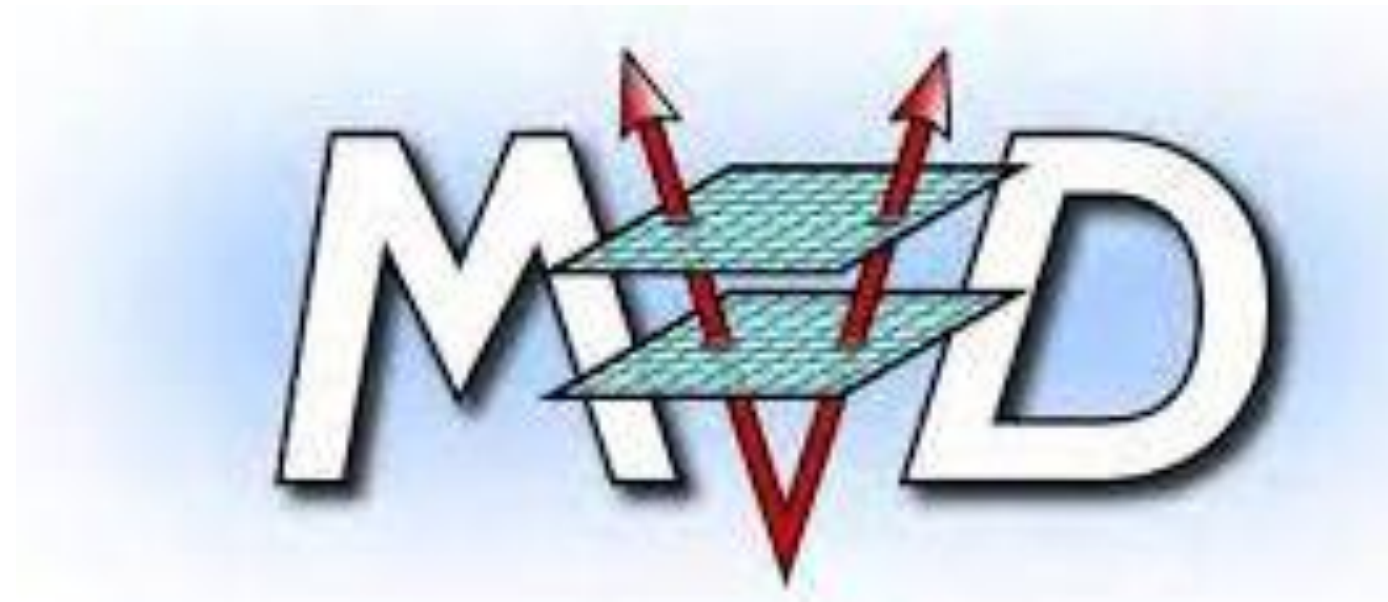


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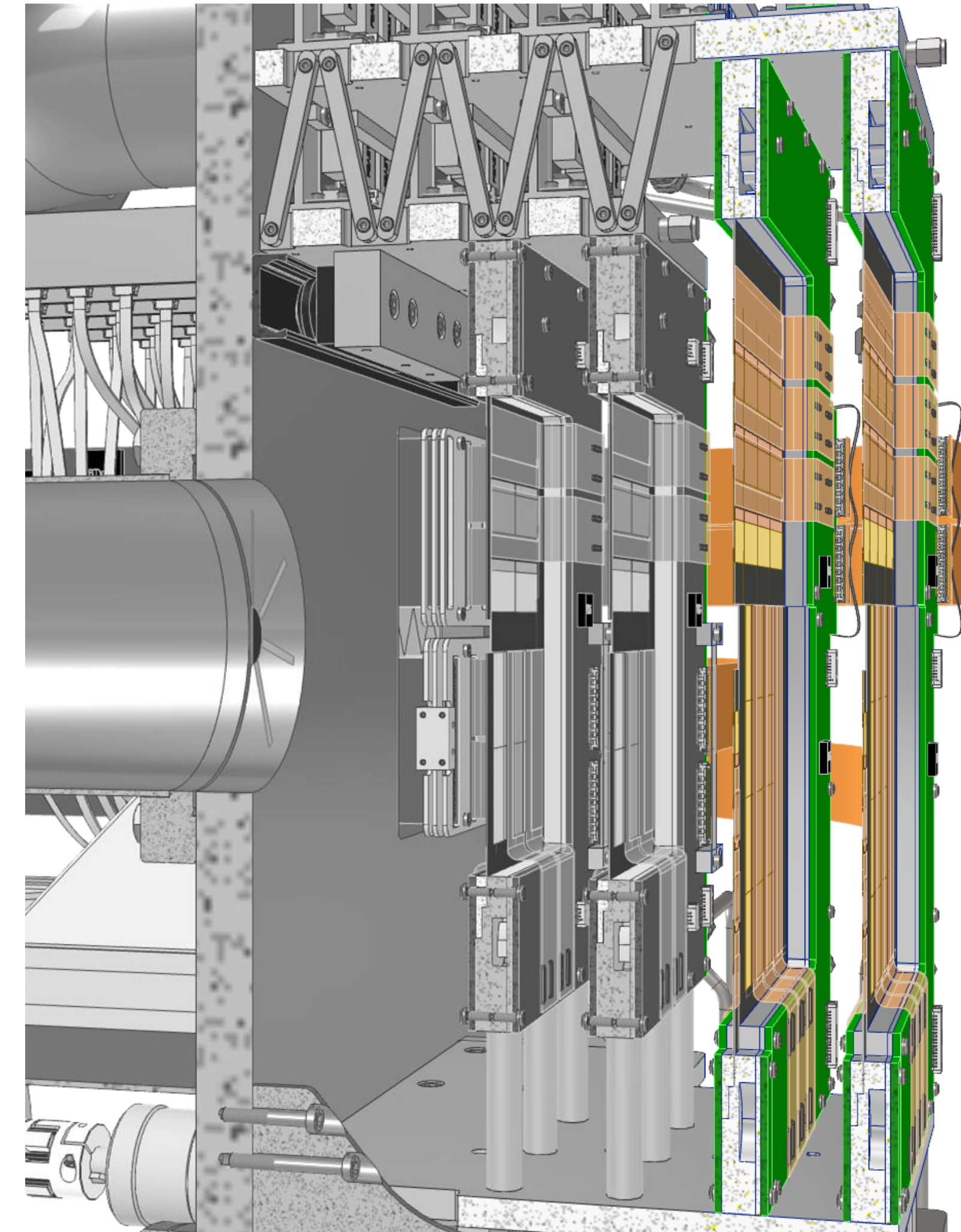
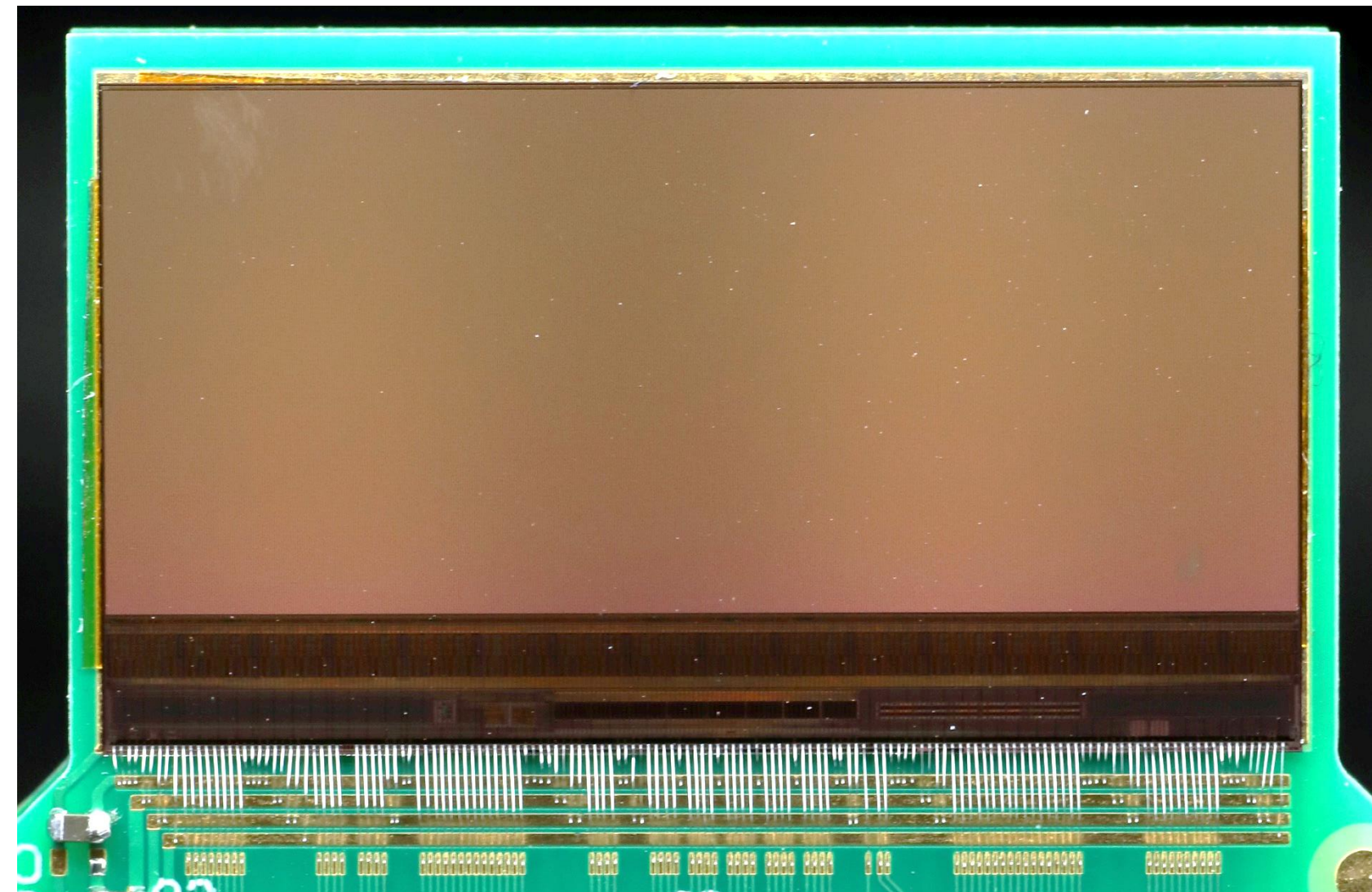




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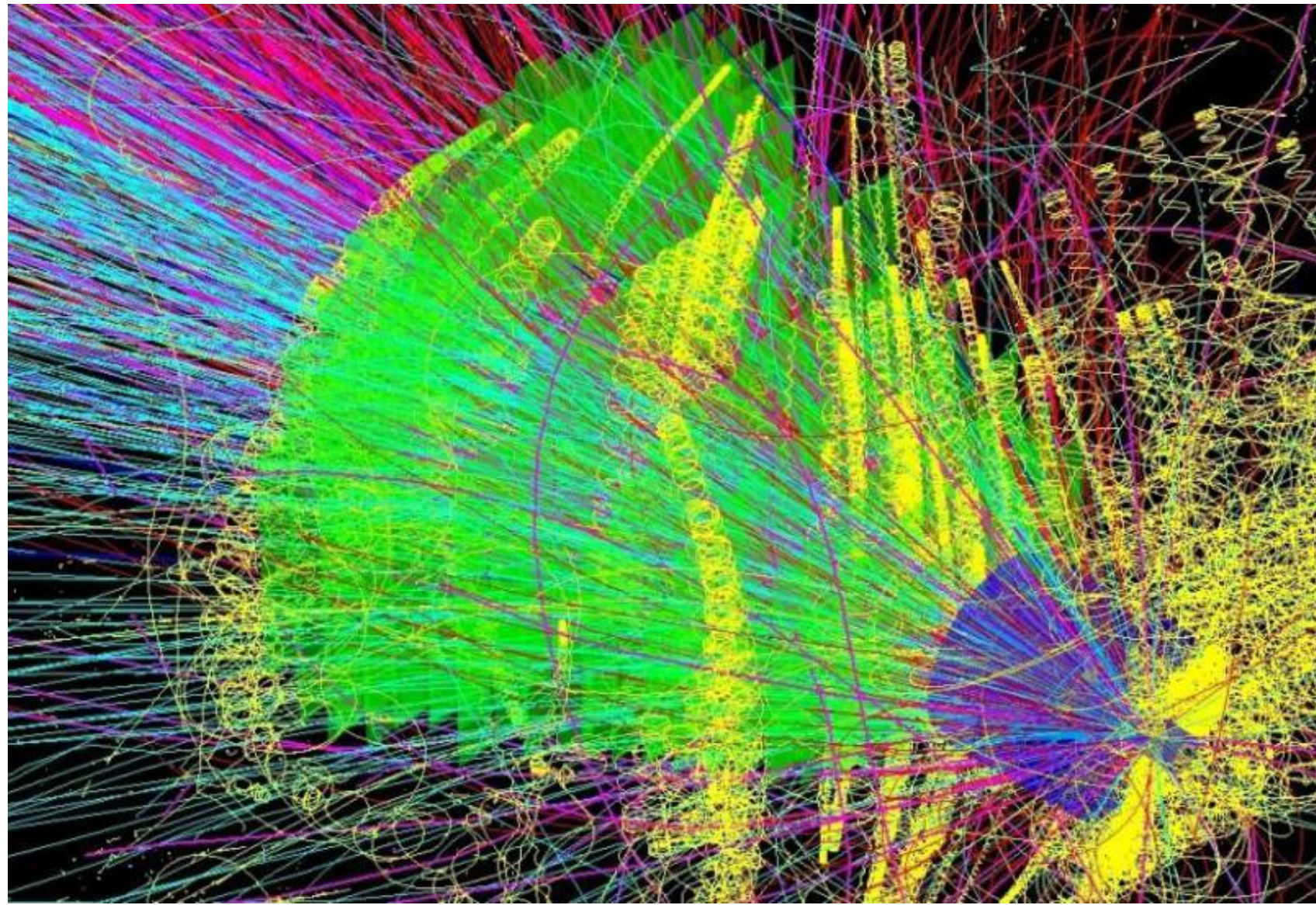


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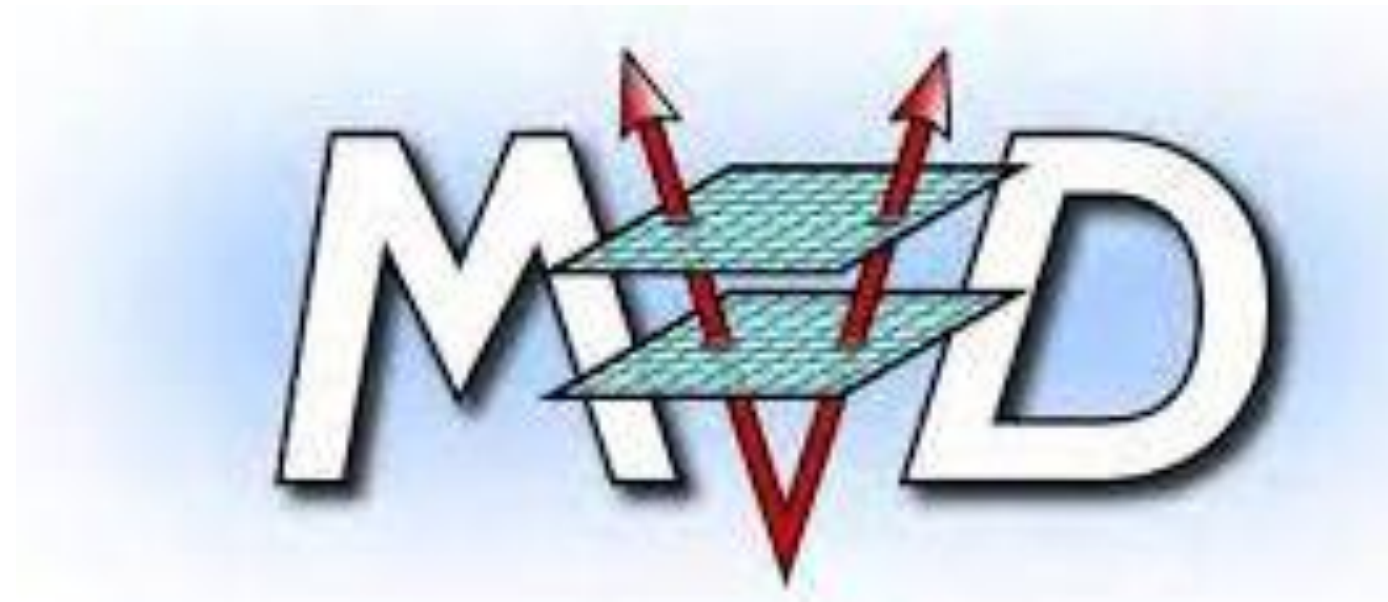


2+2 ultra-low material budget planar  
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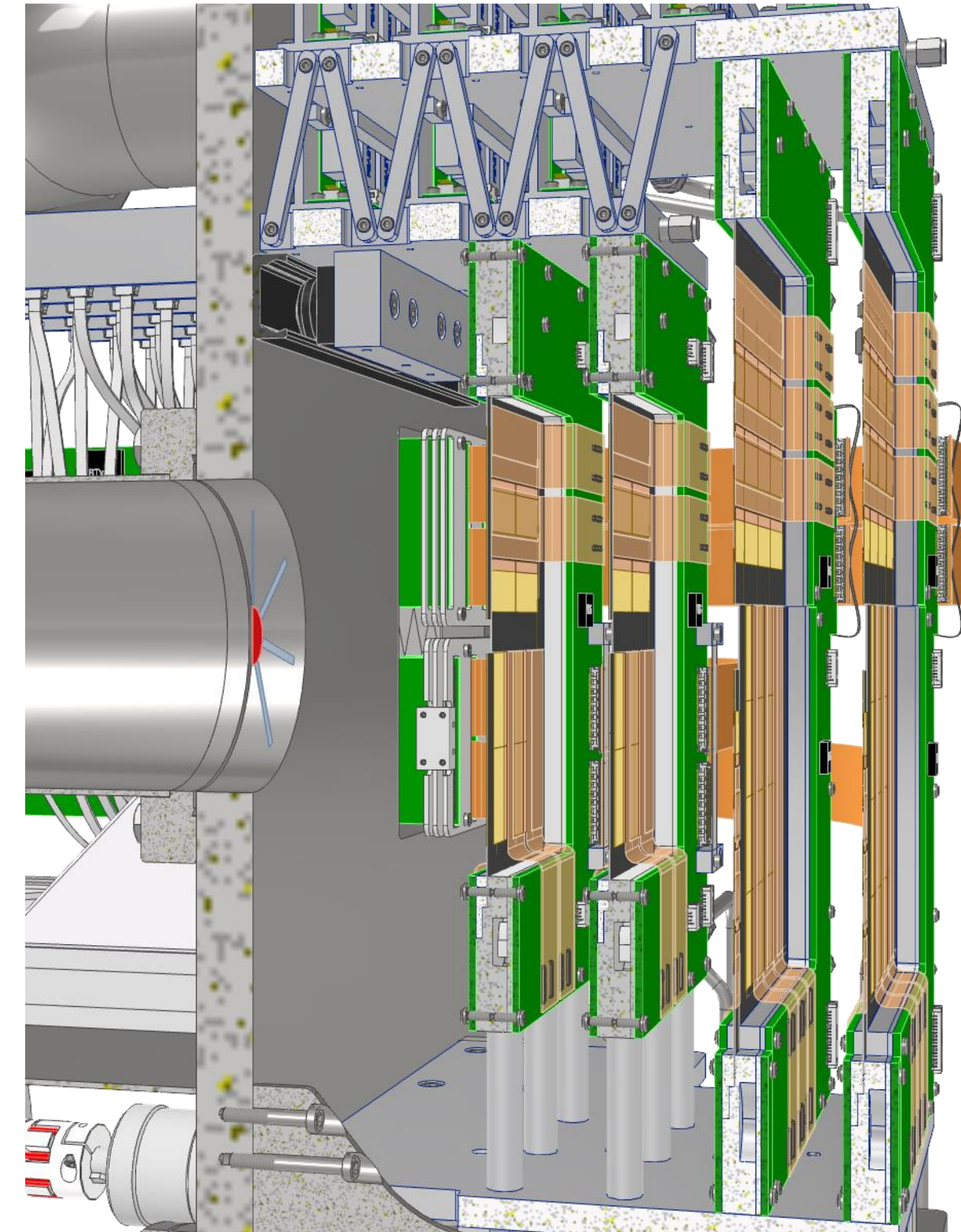
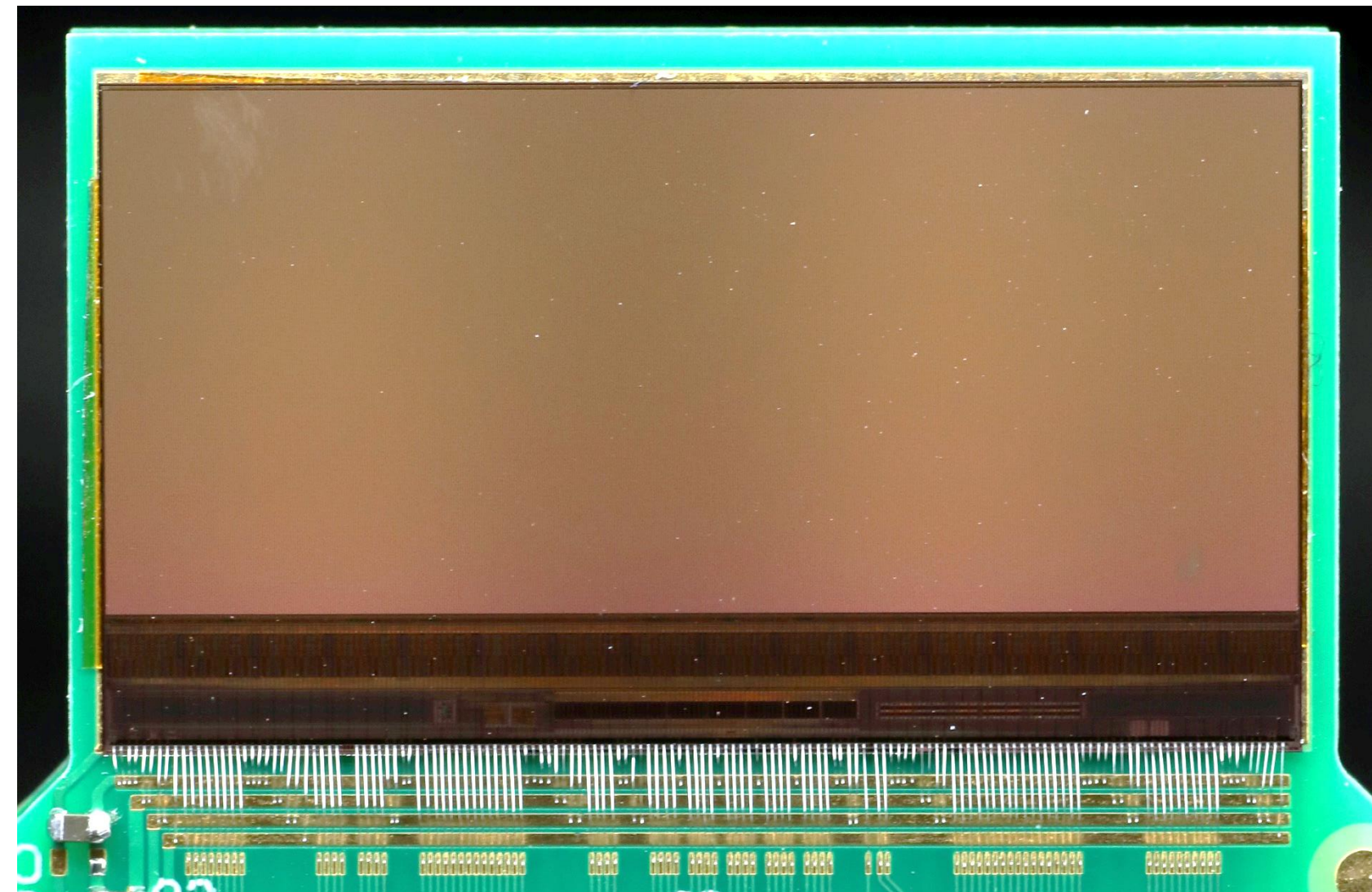




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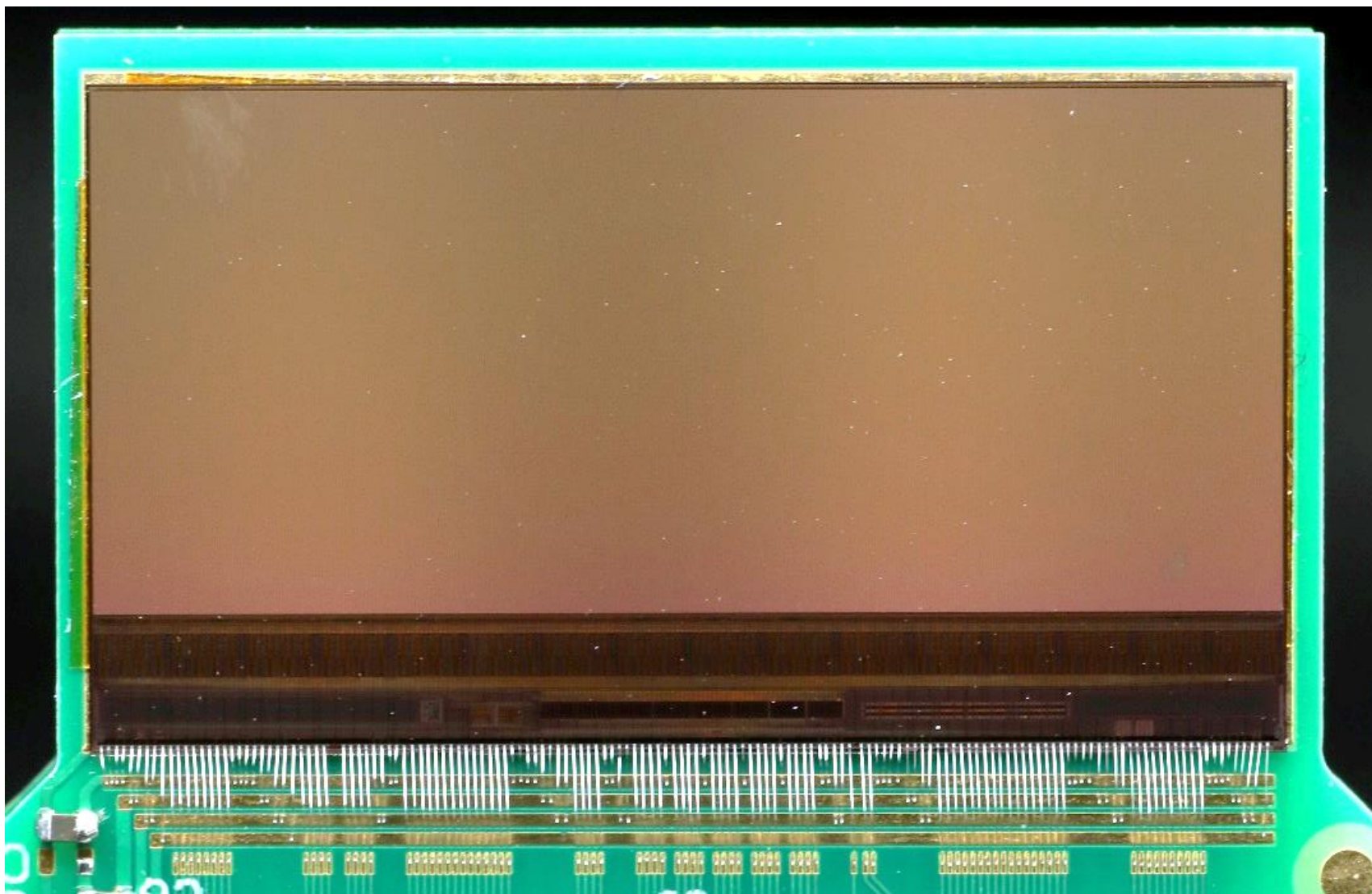


300 CMOS monolithic active  
pixel sensors (MIMOSIS)



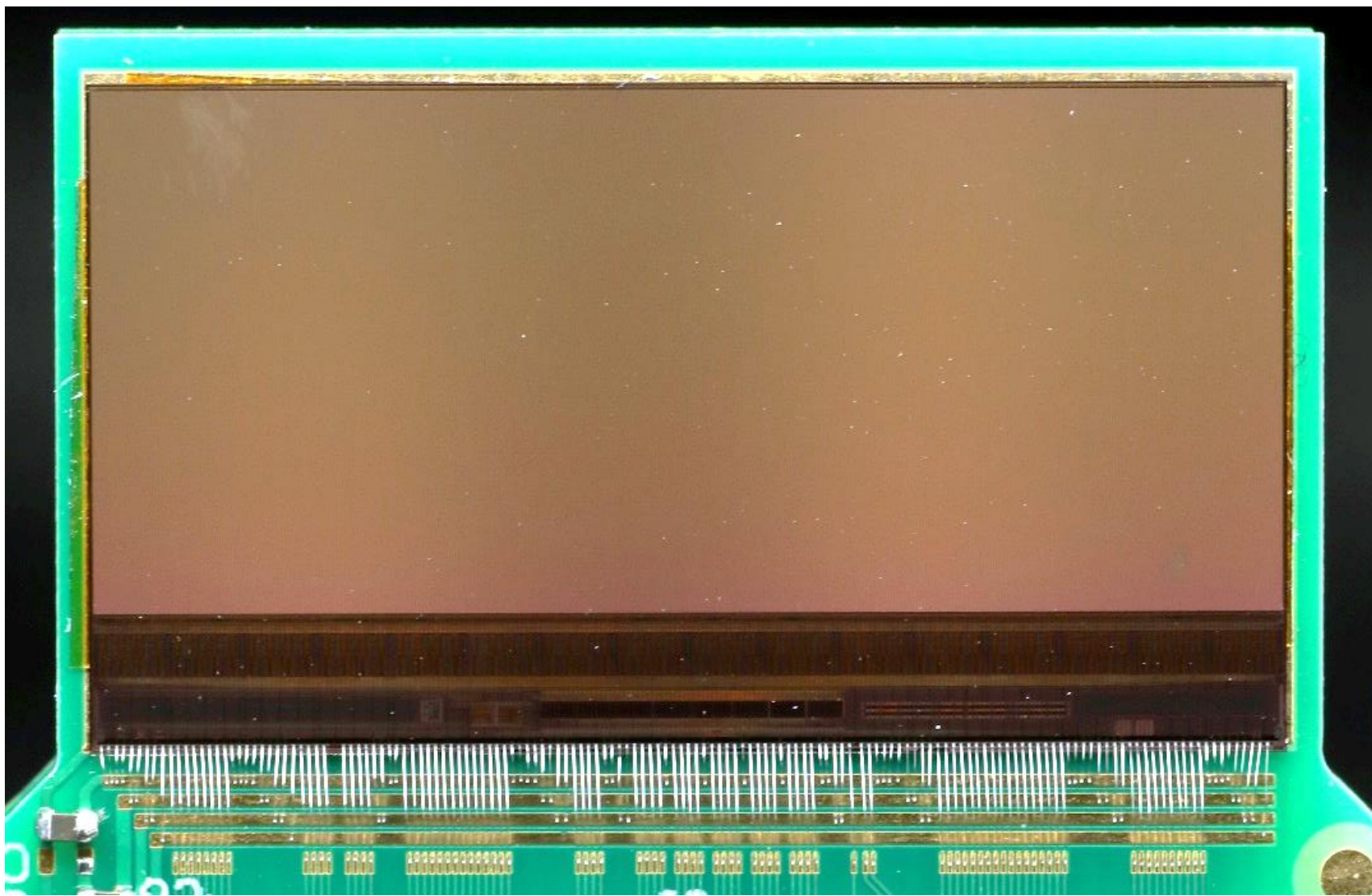
2+2 ultra-low material budget planar  
detector stations in vacuum



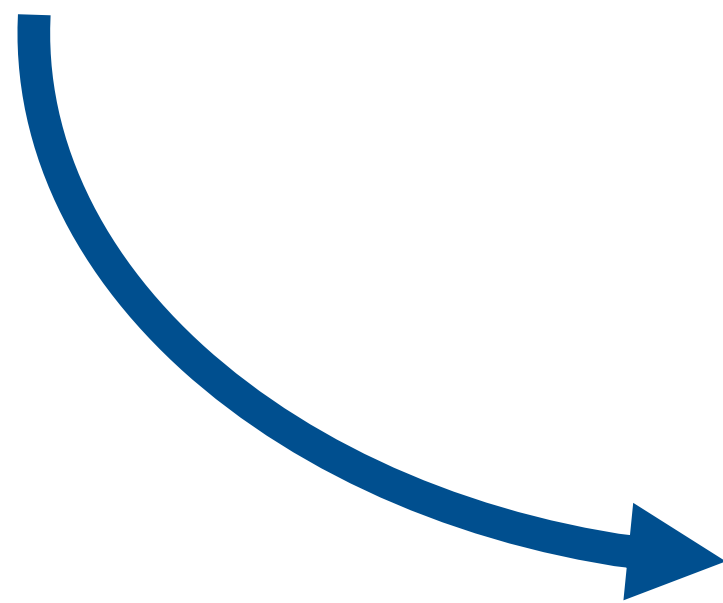


Sensors

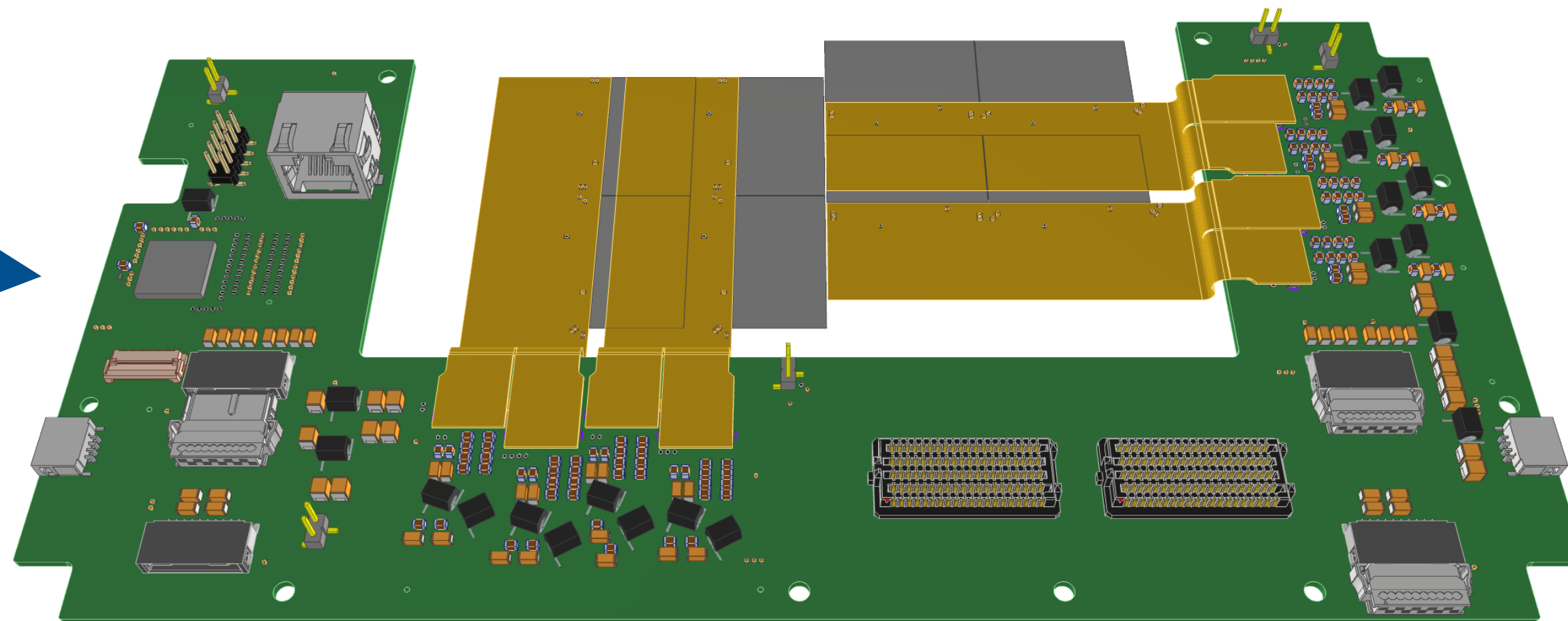




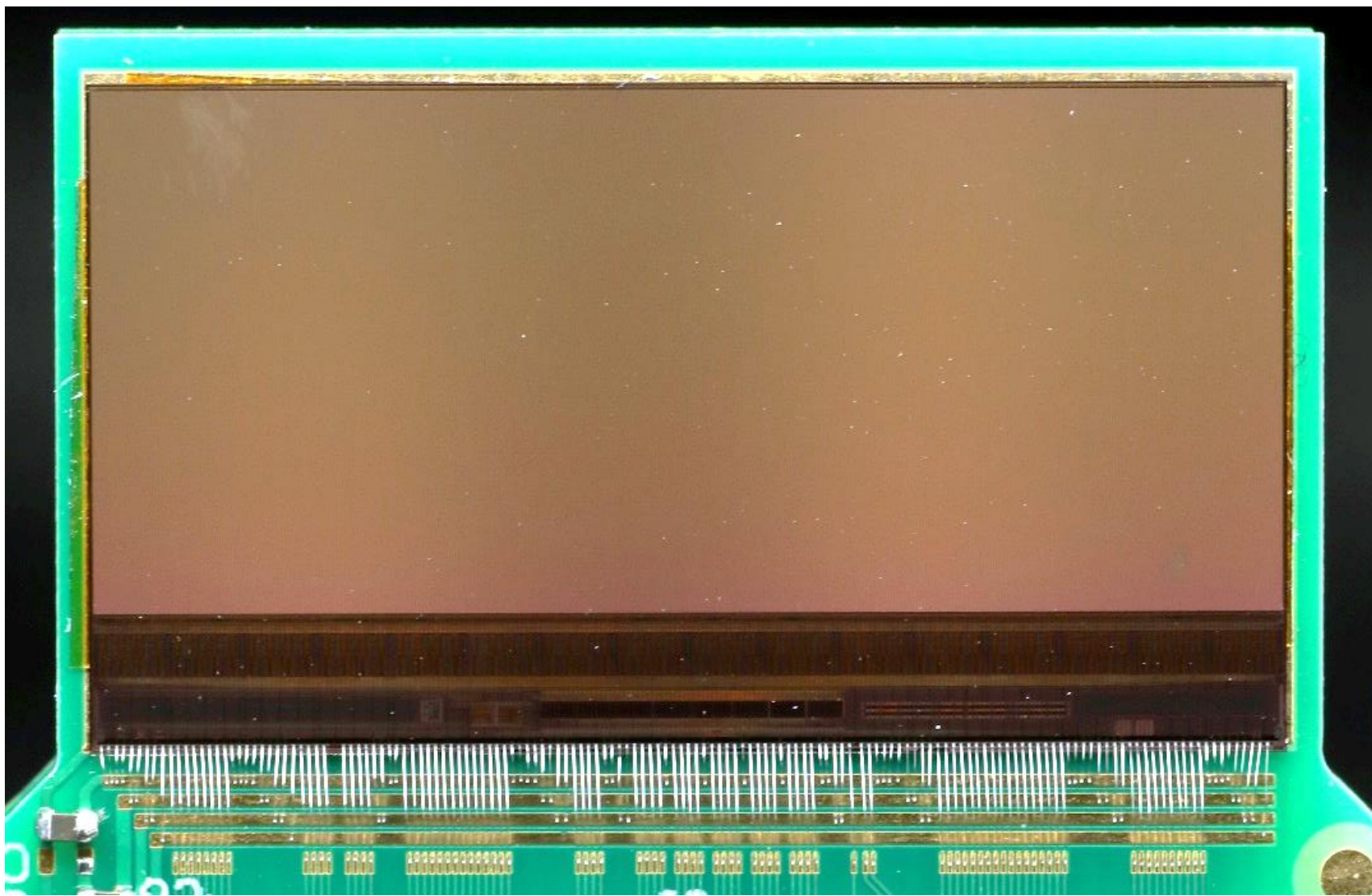
Sensors



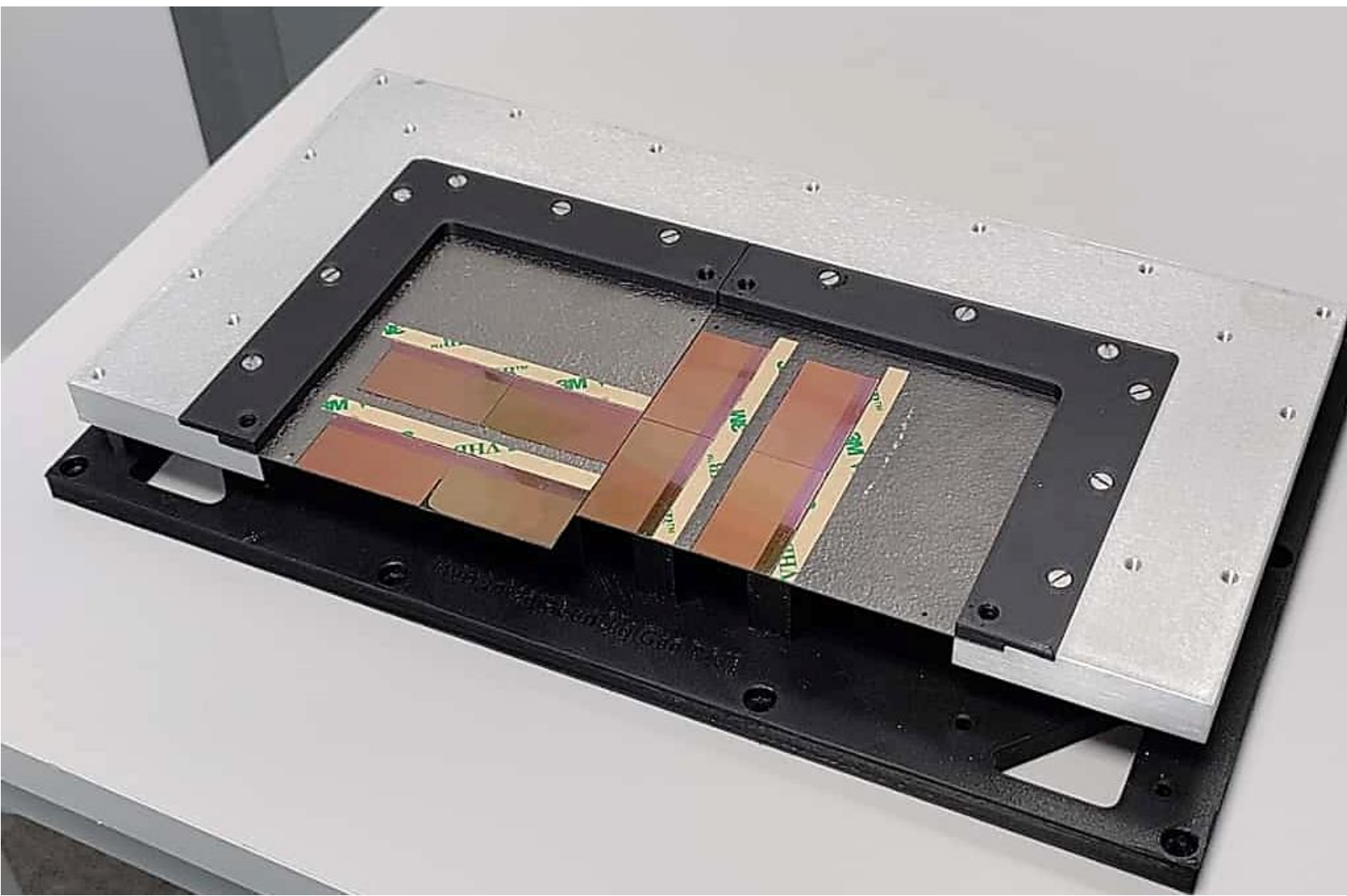
Electronics





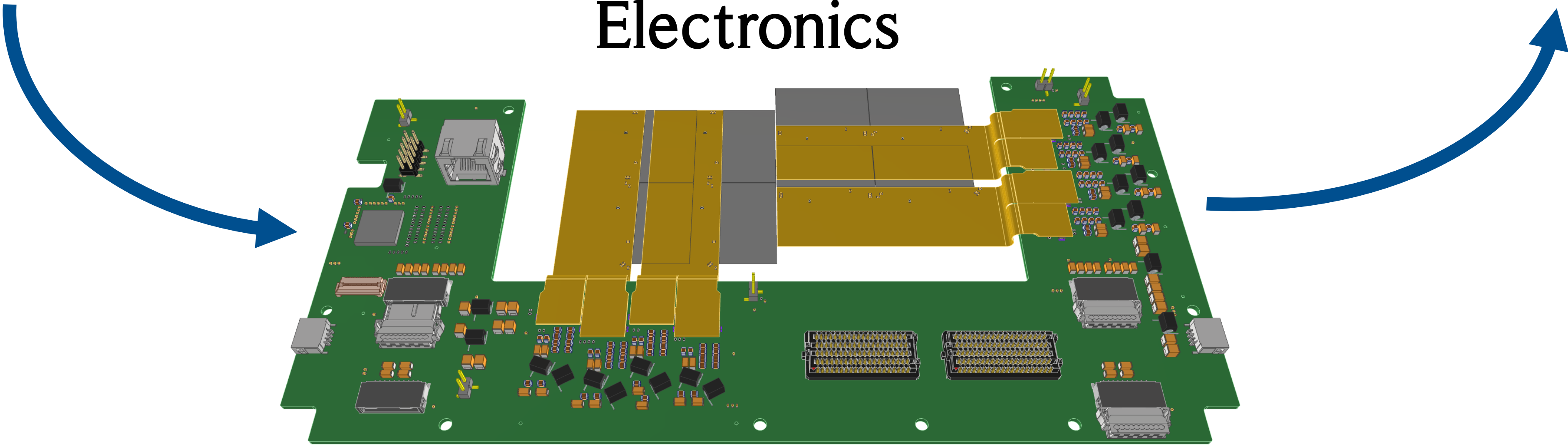


Sensors



Assembly

Electronics





# Towards the MVD Sensor

## Intrinsic Sensor Performance

Radiation hardness

Spatial precision

Time resolution

Detection efficiency

Rate capability

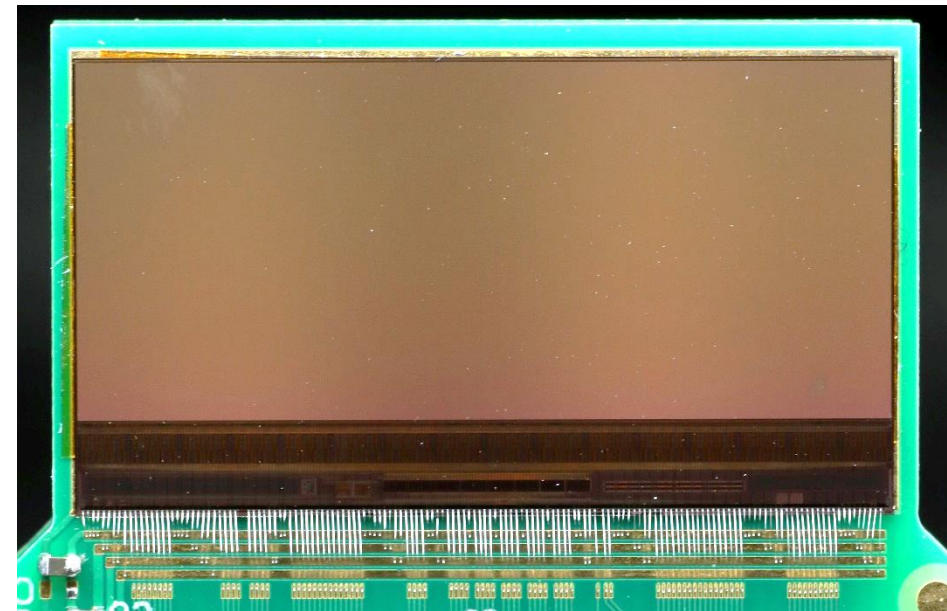
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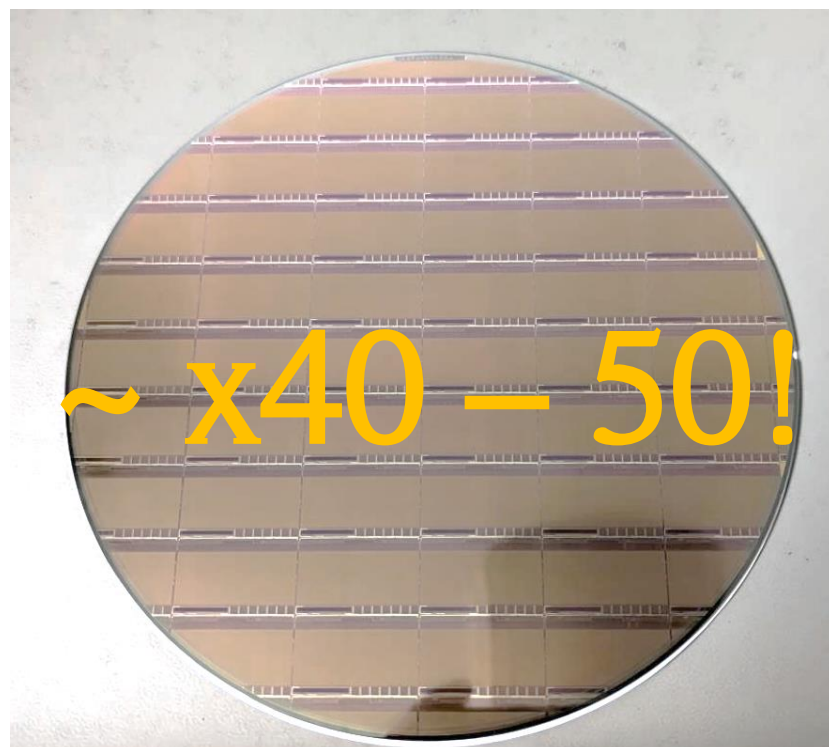
MIMOSIS-0  
2018



MIMOSIS-1  
2020



MIMOSIS-2/2.1  
2024



MIMOSIS-3  
2026

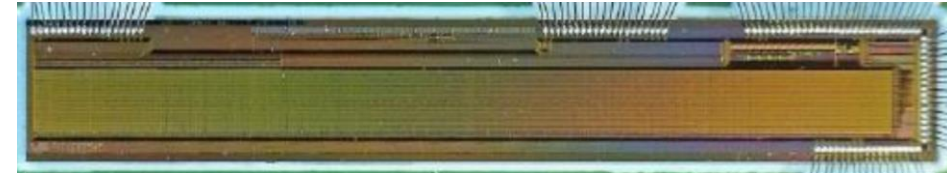




# Towards the MVD Sensor

## Intrinsic Sensor Performance

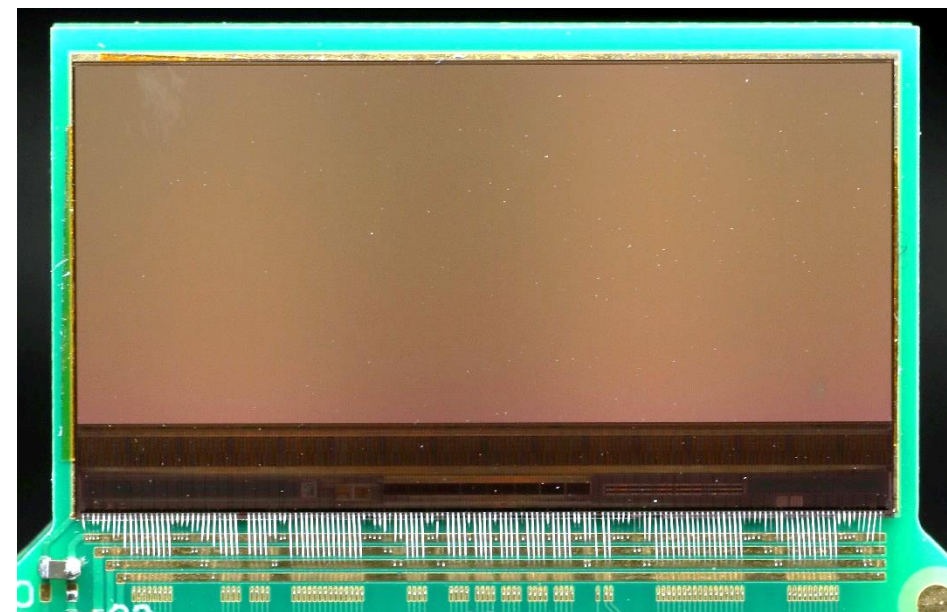
Radiation hardness  
Spatial precision  
Time resolution  
Detection efficiency  
Rate capability  
...



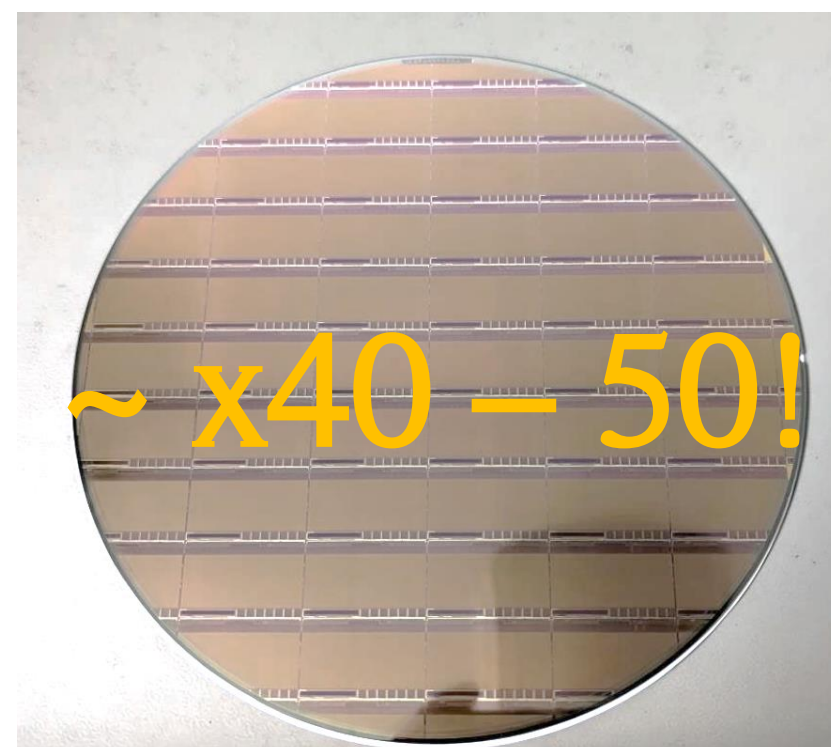
MIMOSIS-0  
2018



MIMOSIS-1  
2020



MIMOSIS-2/2.1  
2024



MIMOSIS-3  
2026

## Sensors in a Detector System

Handling of thin, fragile sensors (50  $\mu\text{m}$ )  
Mass scale testing (~1700 pieces)  
Connectivity  
Power and high-speed signals  
Safety margins and stability of operational parameters  
Reliable slow control and monitoring  
Performance homogeneity (time and space)  
Bandwidth and data handling  
Fail-safety and redundancy  
...

Ongoing...



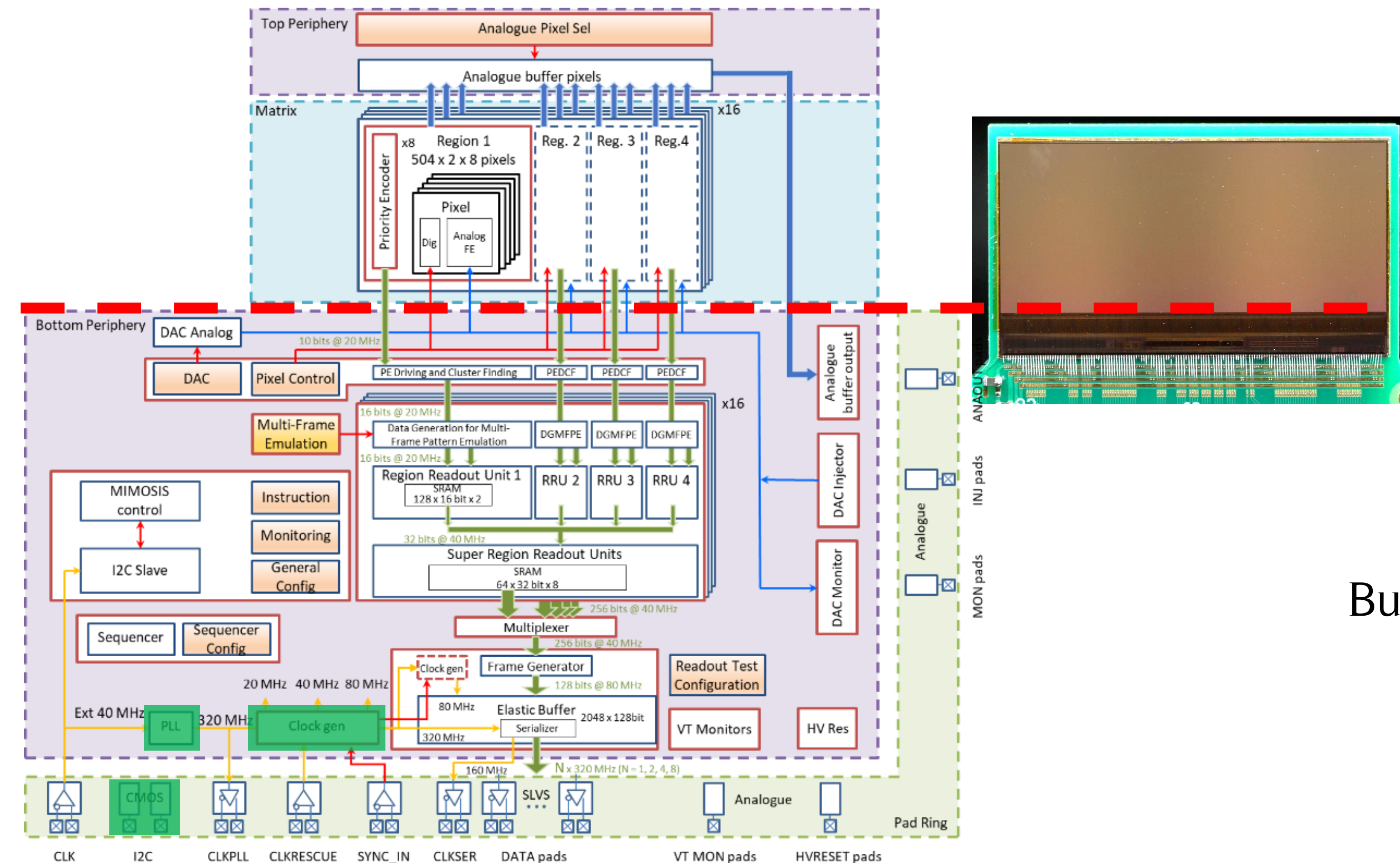
# Improvements in MIMOSIS-3

Performance of std clock (stability)

Full rescue-clock operation (redundancy)

Improved Slow Control In- and Output pads (stability)

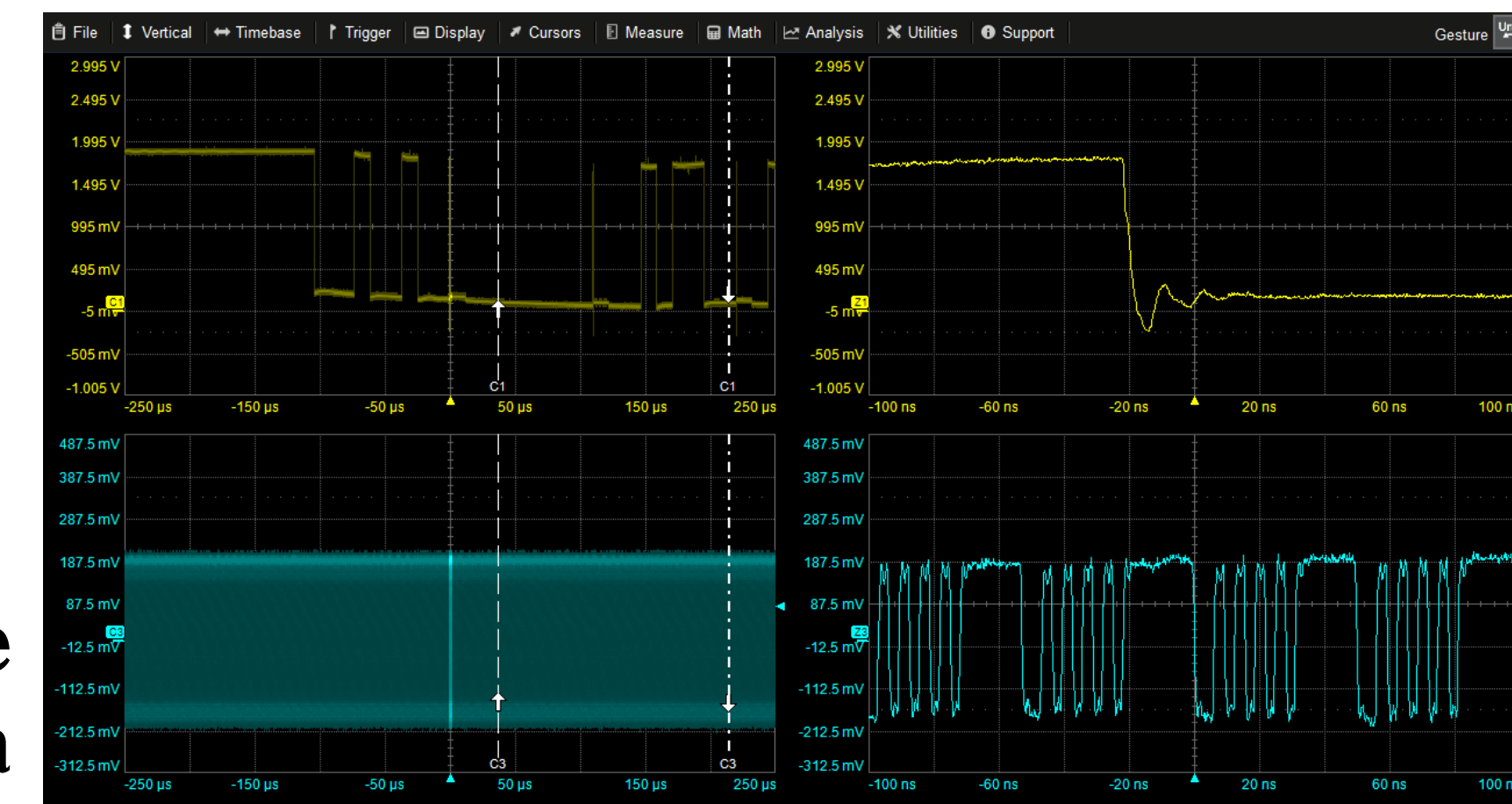
Bug fixes and small changes in power monitoring (monitoring)



Functional Block Diagram MIMOSIS with critical MIMOSIS-3 modifications highlighted

Bene Gutsche, Jan Michel, FM

Correlation I<sup>2</sup>C acknowledge and corrupted data





# Postprocessing and Logistics

Postprocessing (thinning, dicing, picking) company validated (MicroPackS)

Pre-series expected ~05/26 (12 wafers, ~400 dies, Tower Semiconductor)

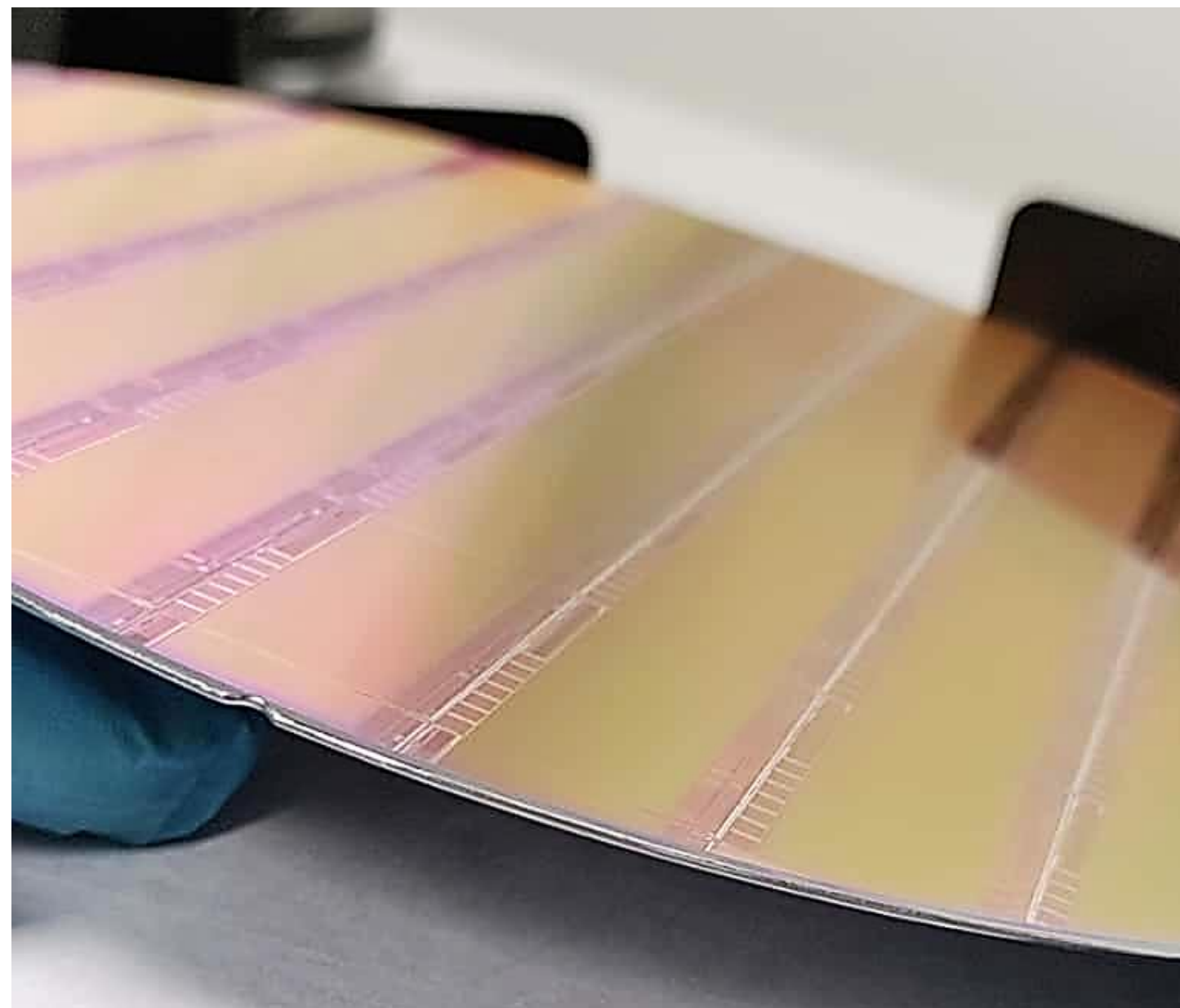
→ Logistics to be optimized

→ FAI protocol

→ Pre-irradiation (parameter stability)

→ FOS module production

→ Final production (~40 – 50 wafers, ~1.7k dies)



MIMOSIS-2 wafer before  
thinning and dicing

MIMOSIS-2.1 die  
thinned to 50  $\mu\text{m}$



Dedicated transport boxes for 50  $\mu\text{m}$   
sensors (ALPIDE inspired)



# Mass Testing the MIMOSIS

Probe test as QA before integration

→ Modules with up to 28 sensors

QA optimization

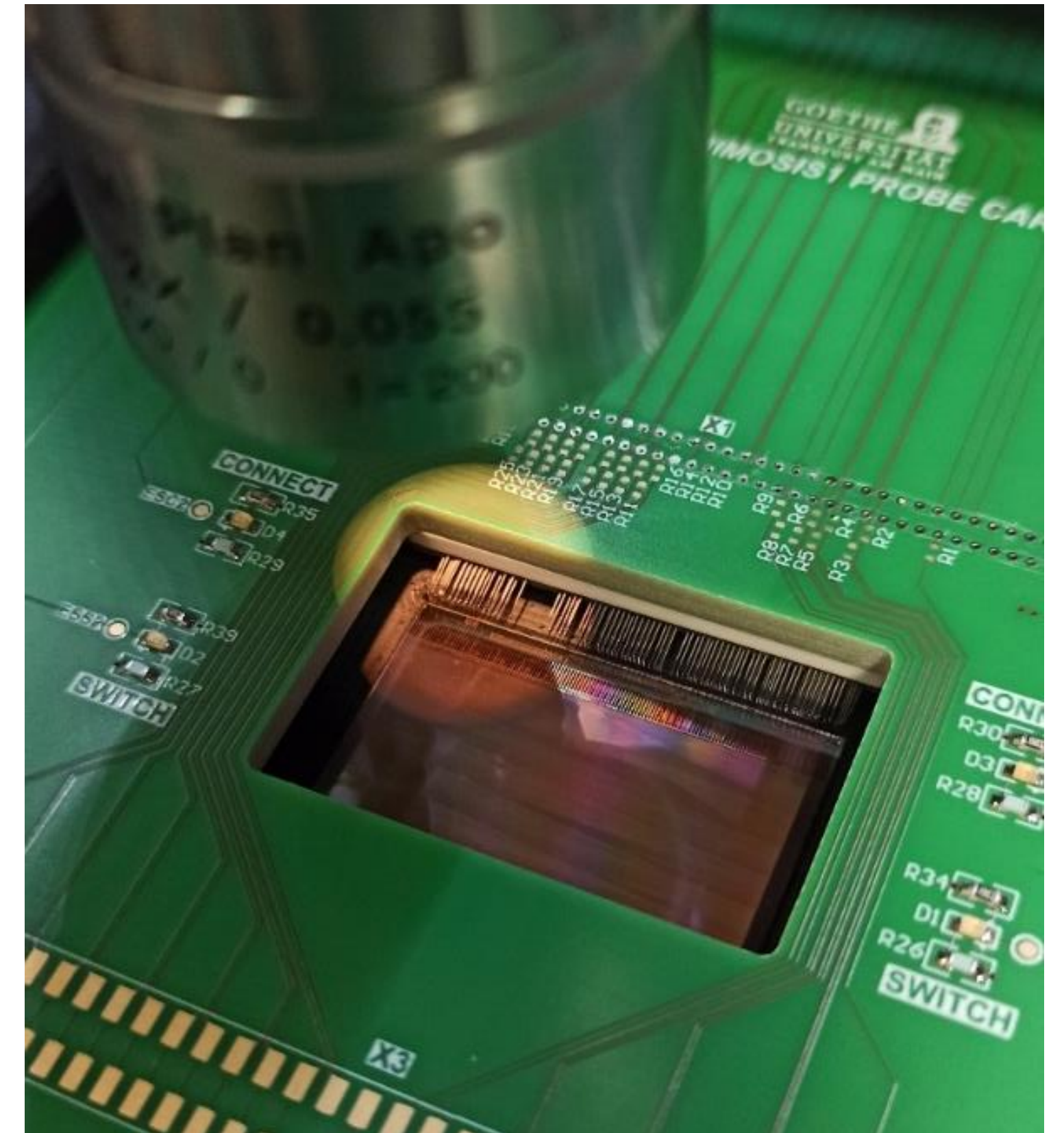
→ 60 min per usable sensor (~2 min for unusable)

Yield of 55% after thinning and dicing (based on ~60 sensors)

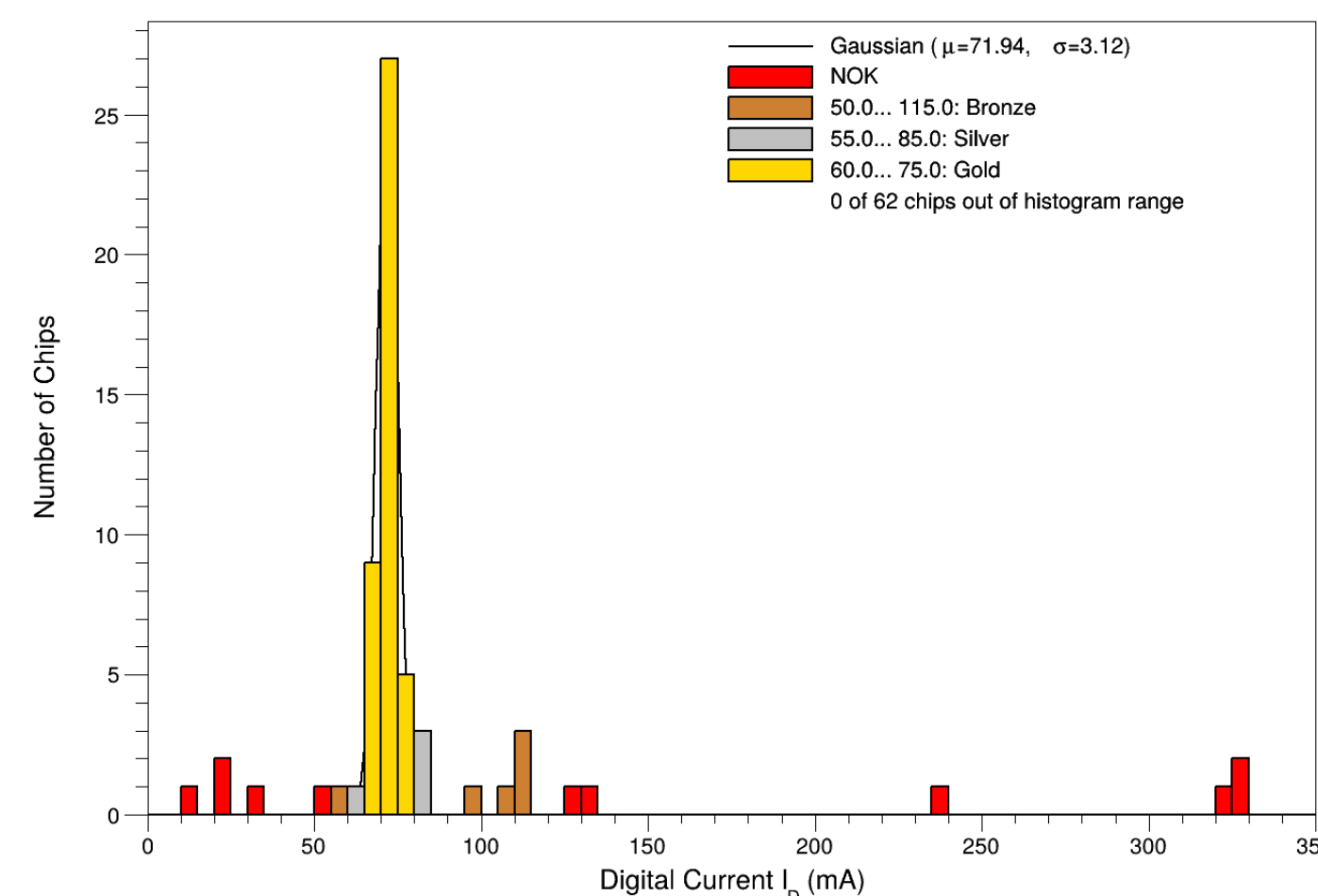
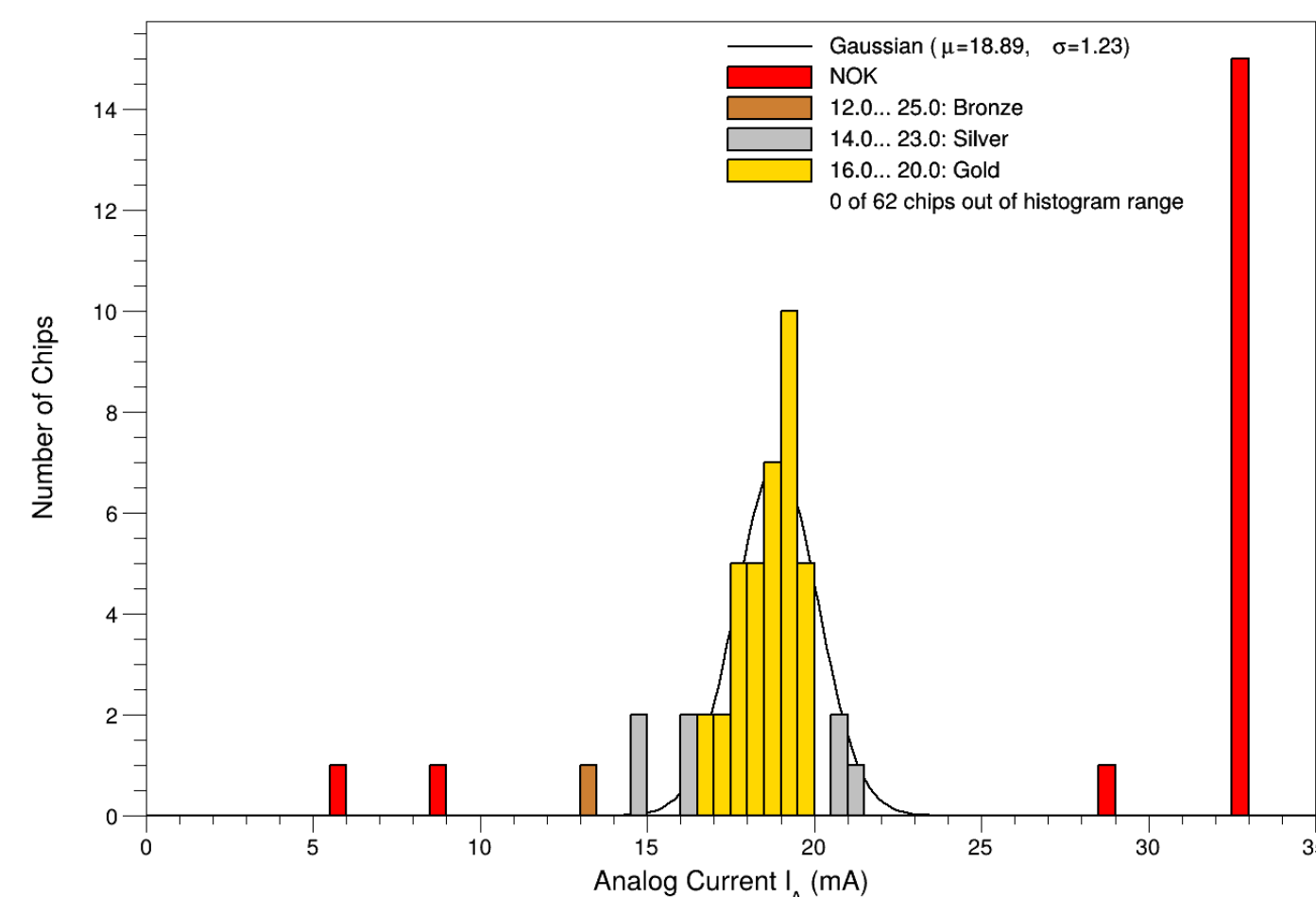
→ ALPIDE-like

→ 2-3 months total testing time MIMOSIS-3

Deportable system is in preparation



MIMOSIS-2.1 contacted by  
probe needles

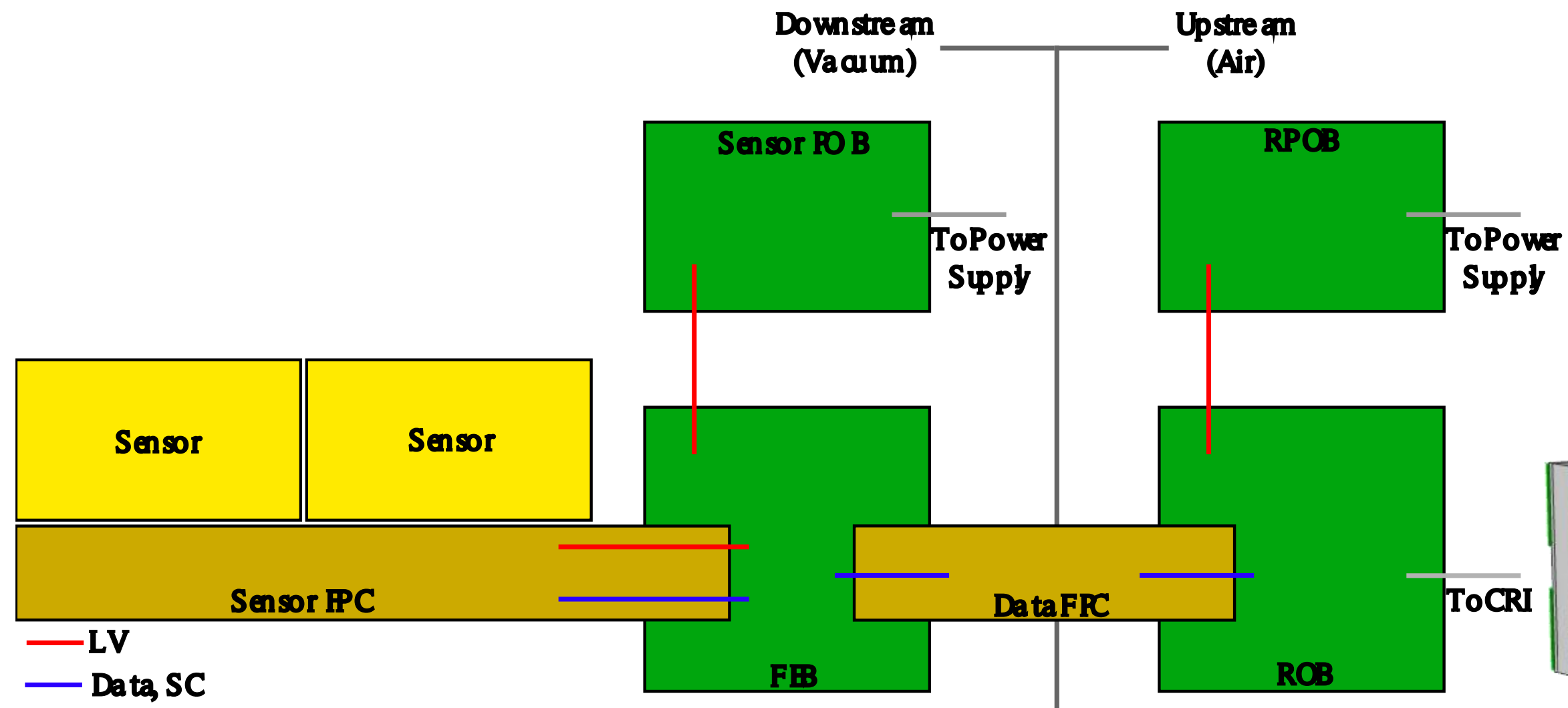


Analog & digital  
power consumption

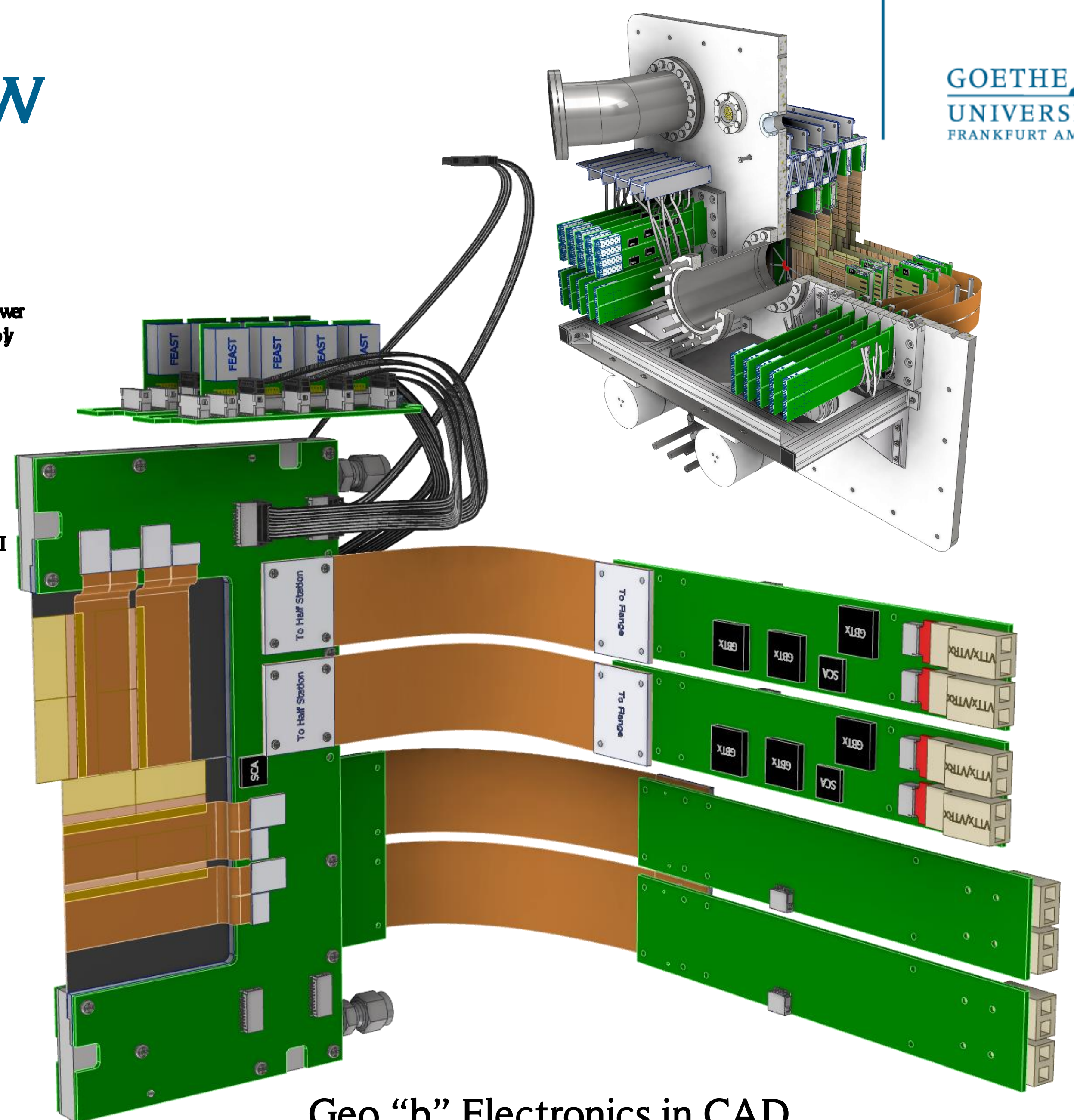
Bene Gutsche, Ben Meadows, FM



# MVD Electrical Overview



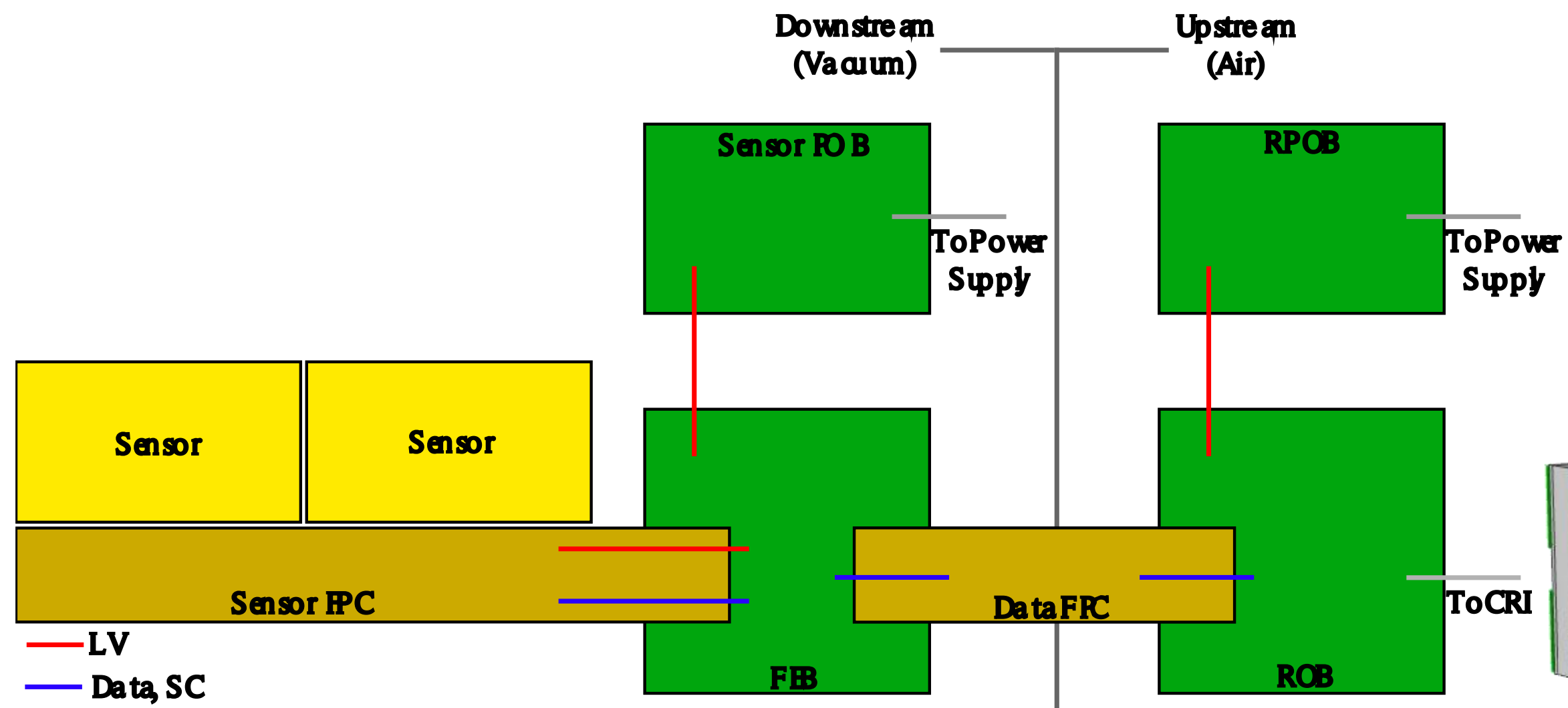
MVD Electronics Scheme



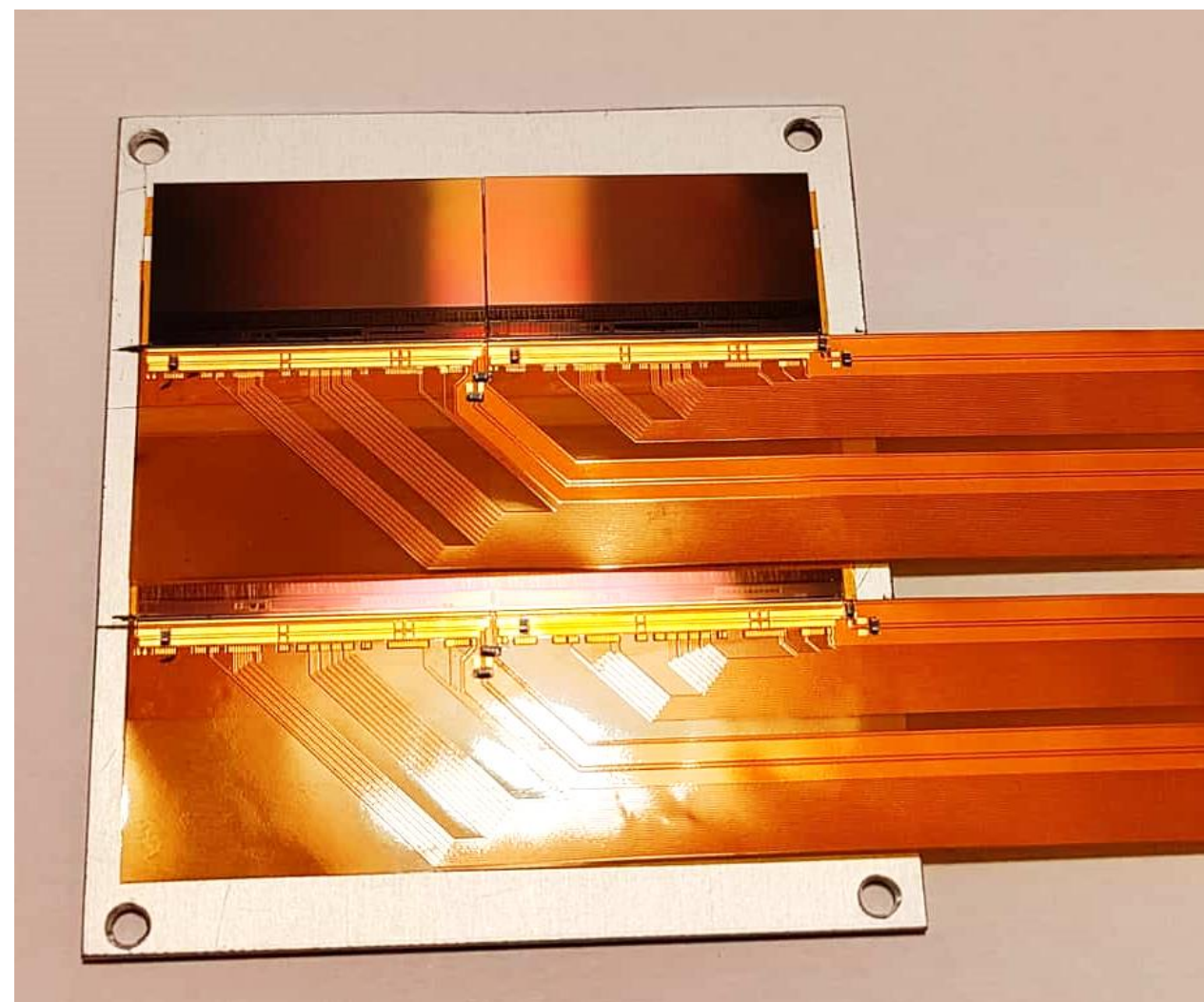
Geo "b" Electronics in CAD



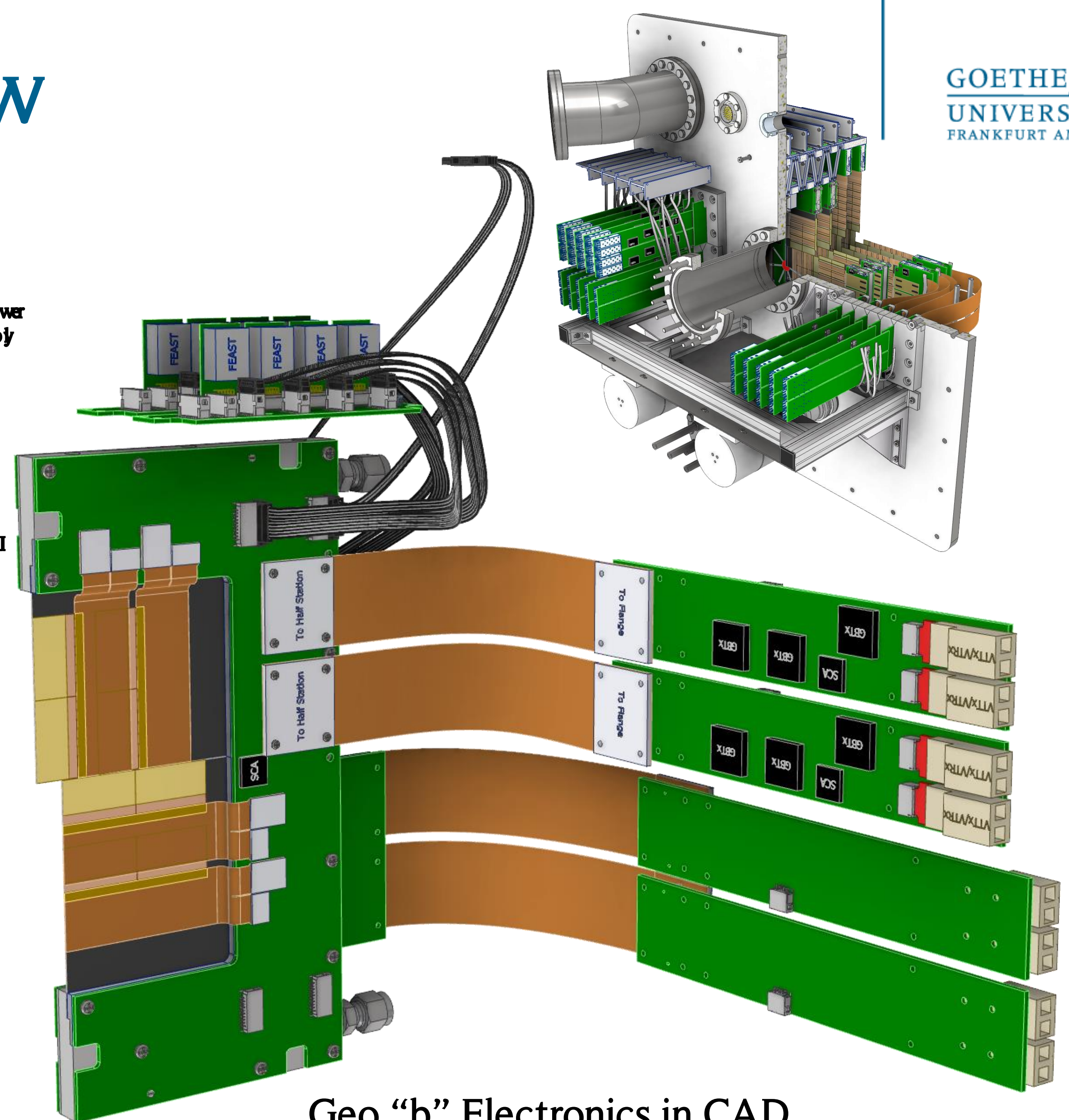
# MVD Electrical Overview



## MVD Electronics Scheme



MIMOSIS-2.1 with MVD FPC



Geo "b" Electronics in CAD



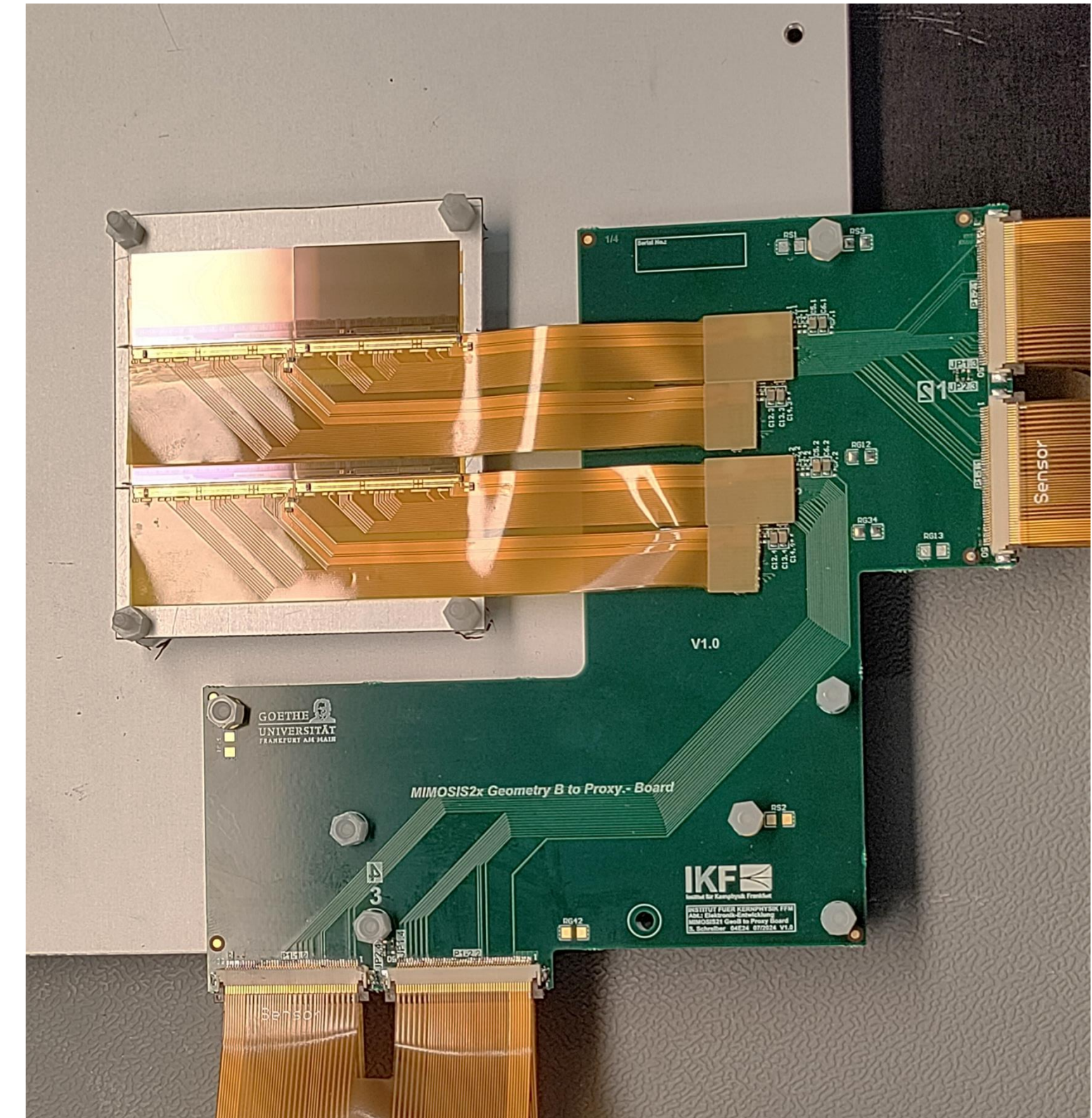
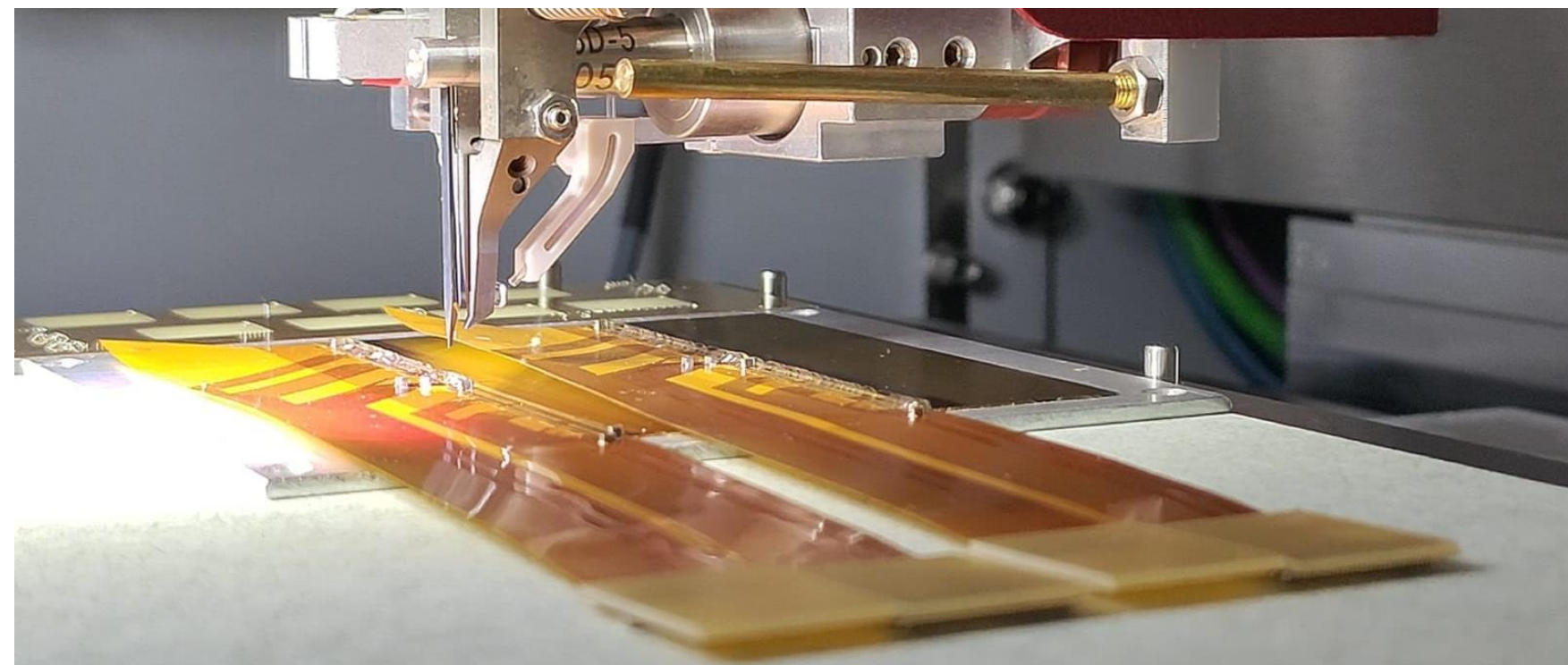
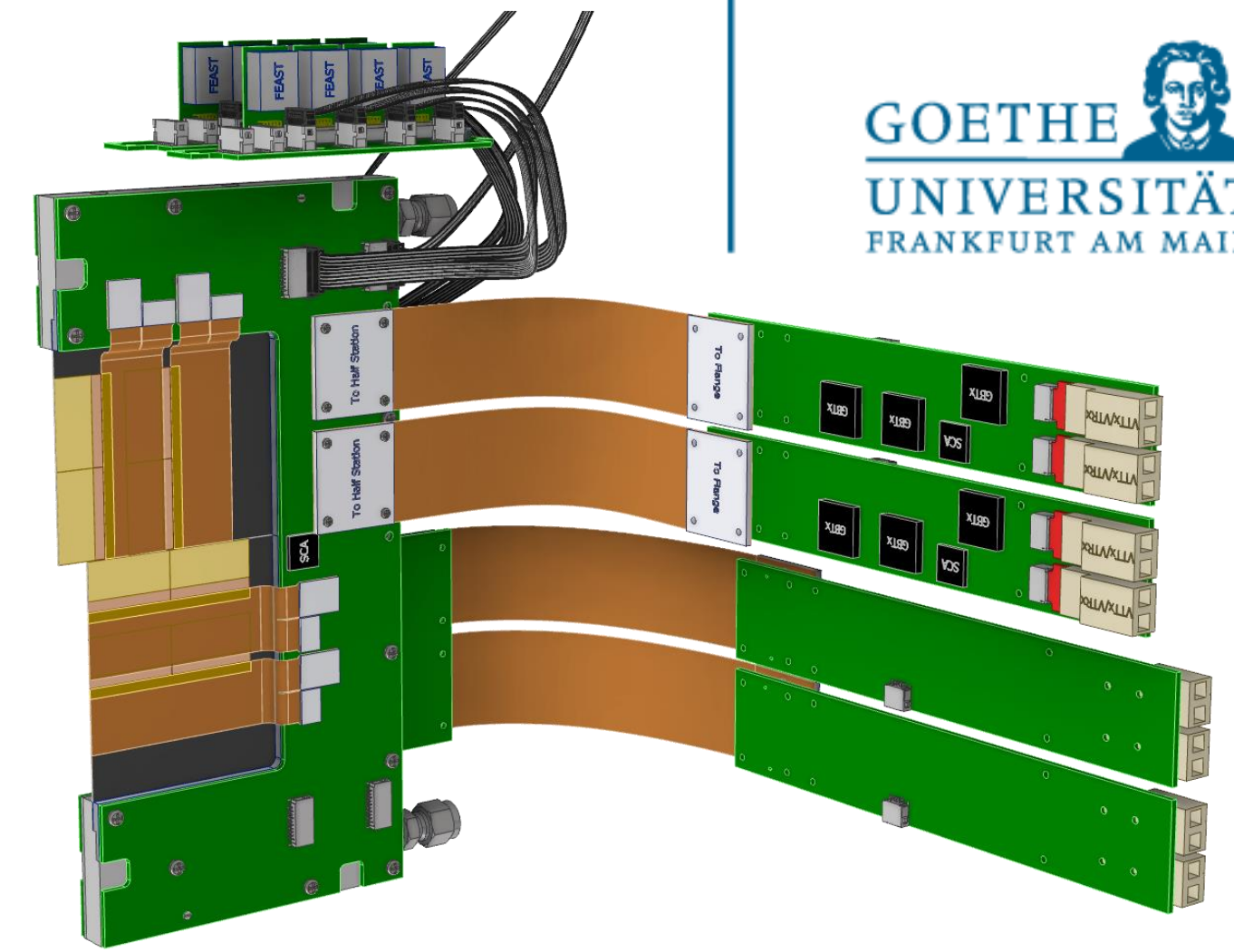
# MIMOSIS in an MVD Setting

Sensing element optimized in “clean” environment

First iteration sensor FPC and 2 modules with 4 MIMOSIS-2.1

- Station geo “b” frontside
- Probe tested, full-automatic bonding
- Functionality confirmed after integration
- 2 0402 capacitors per sensor in acceptance, adds  $\sim 0.03\%$   $X_0$  (avg)

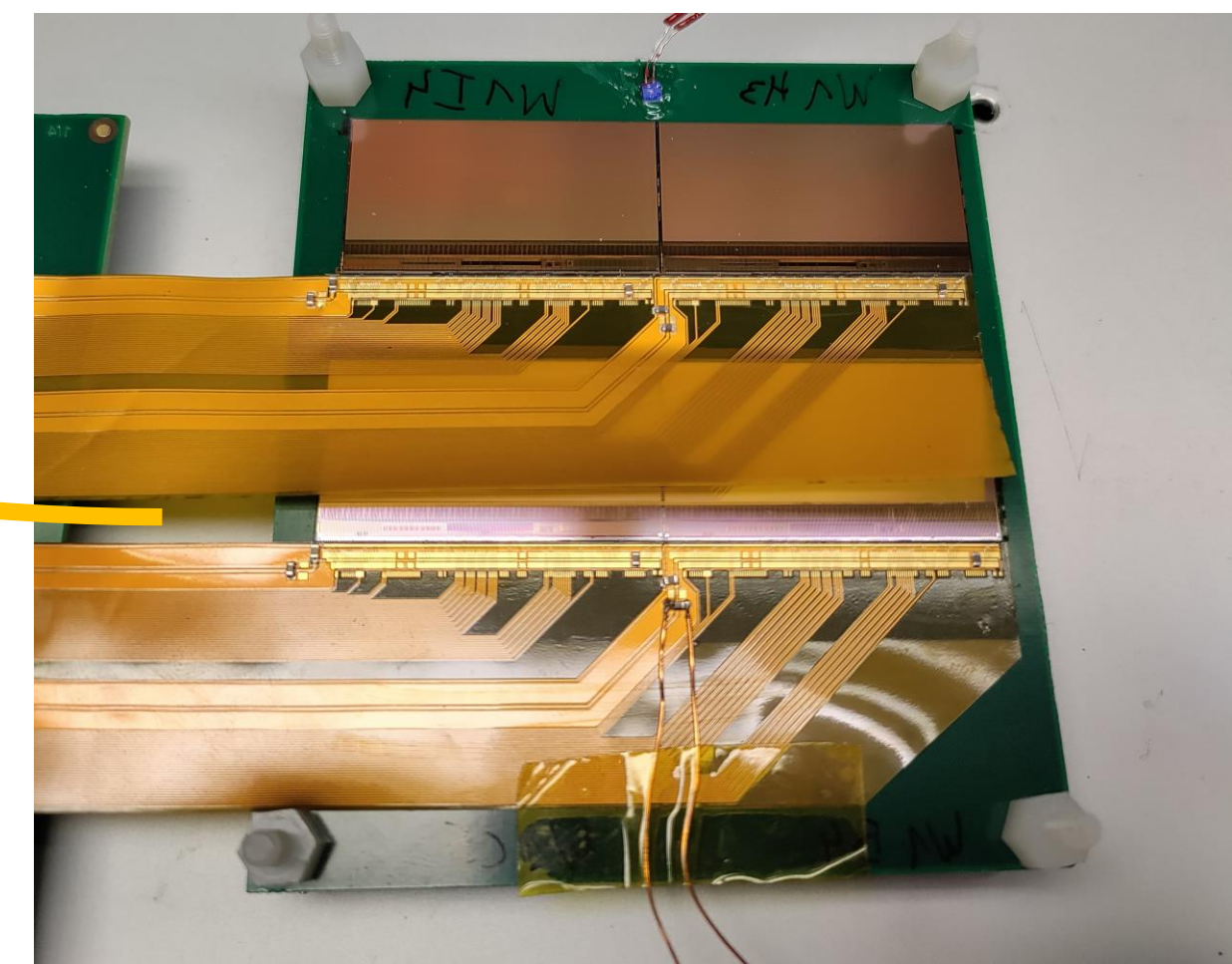
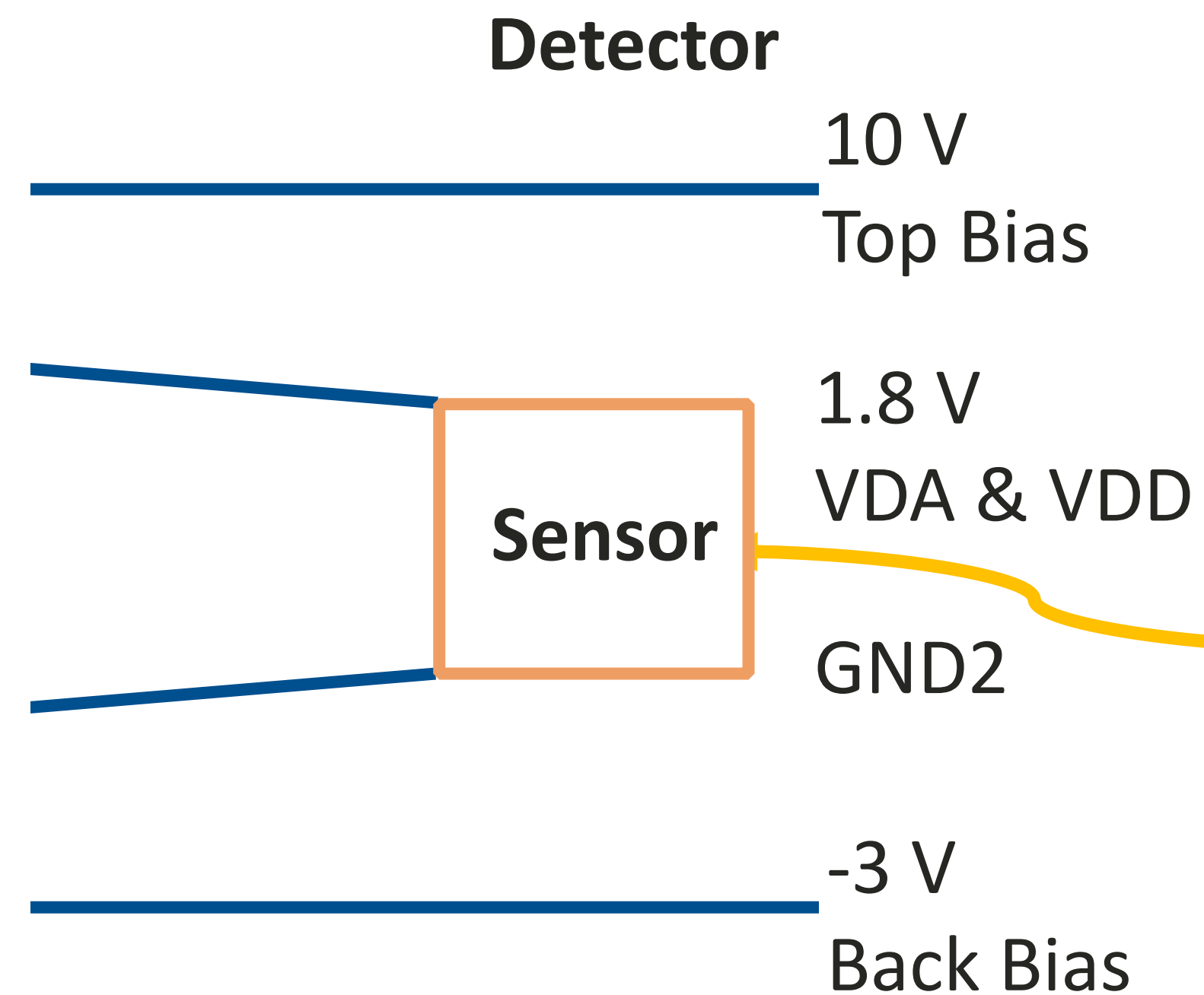
Key input for electronics design and integration





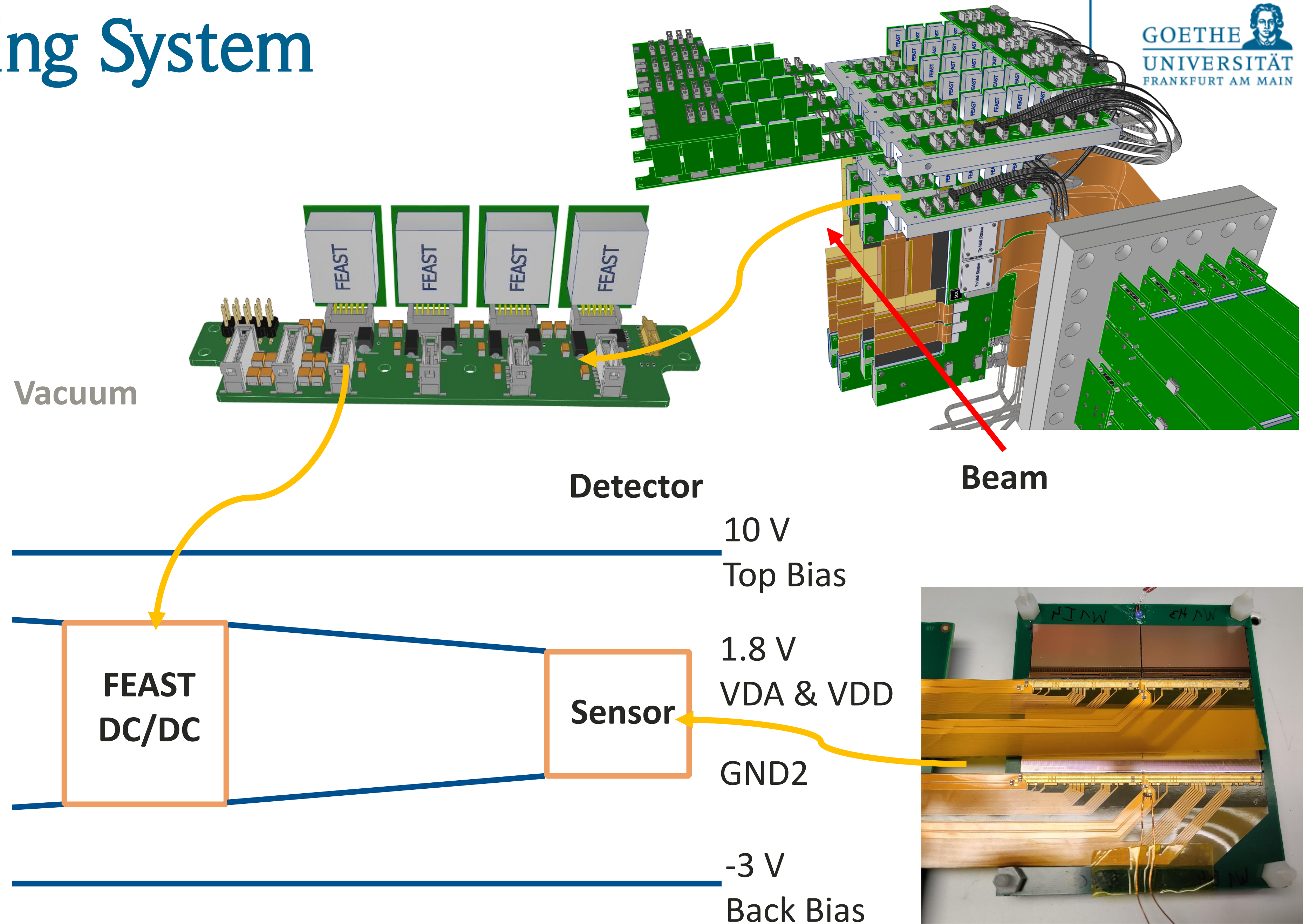
# MVD Powering System

Vacuum



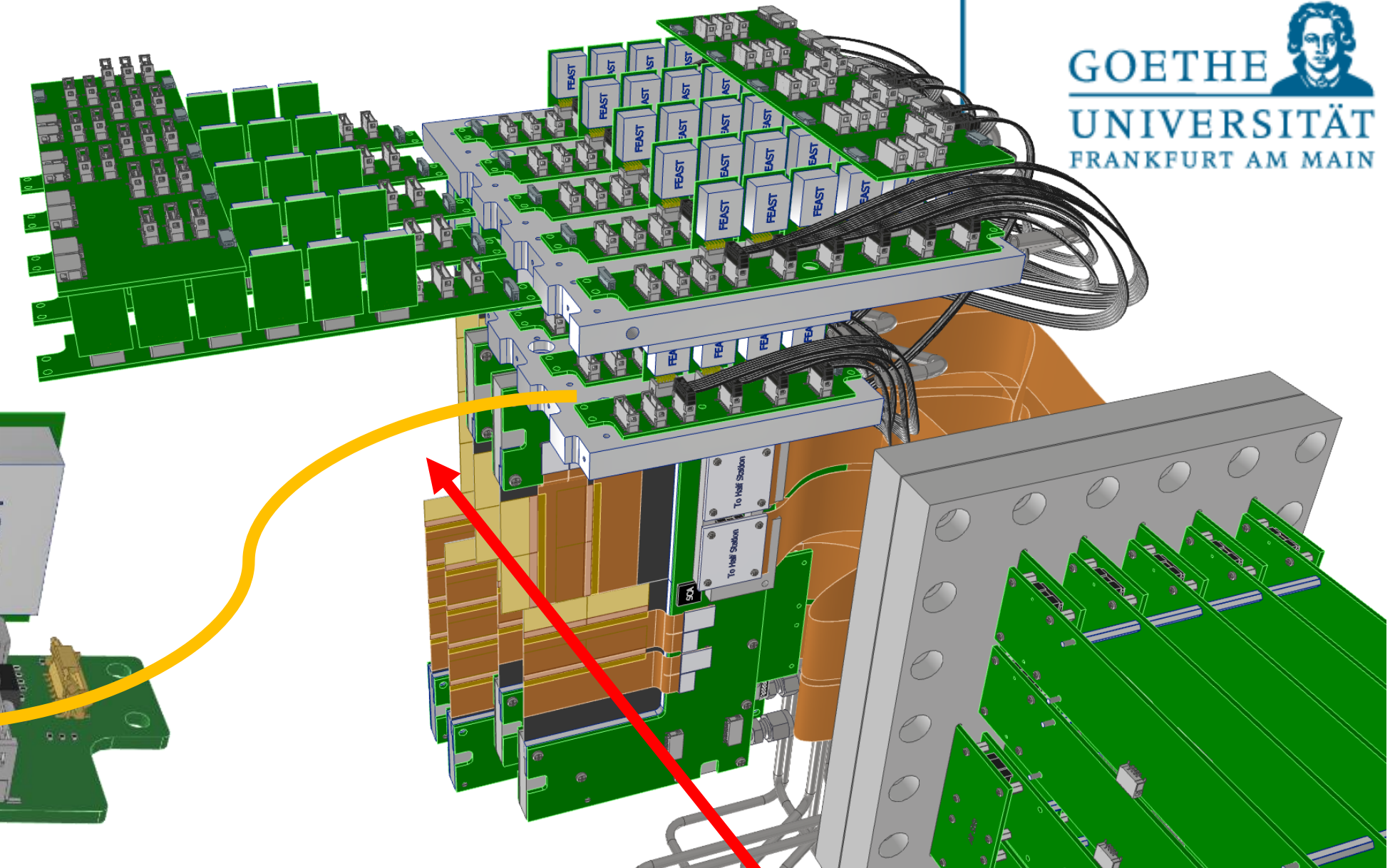
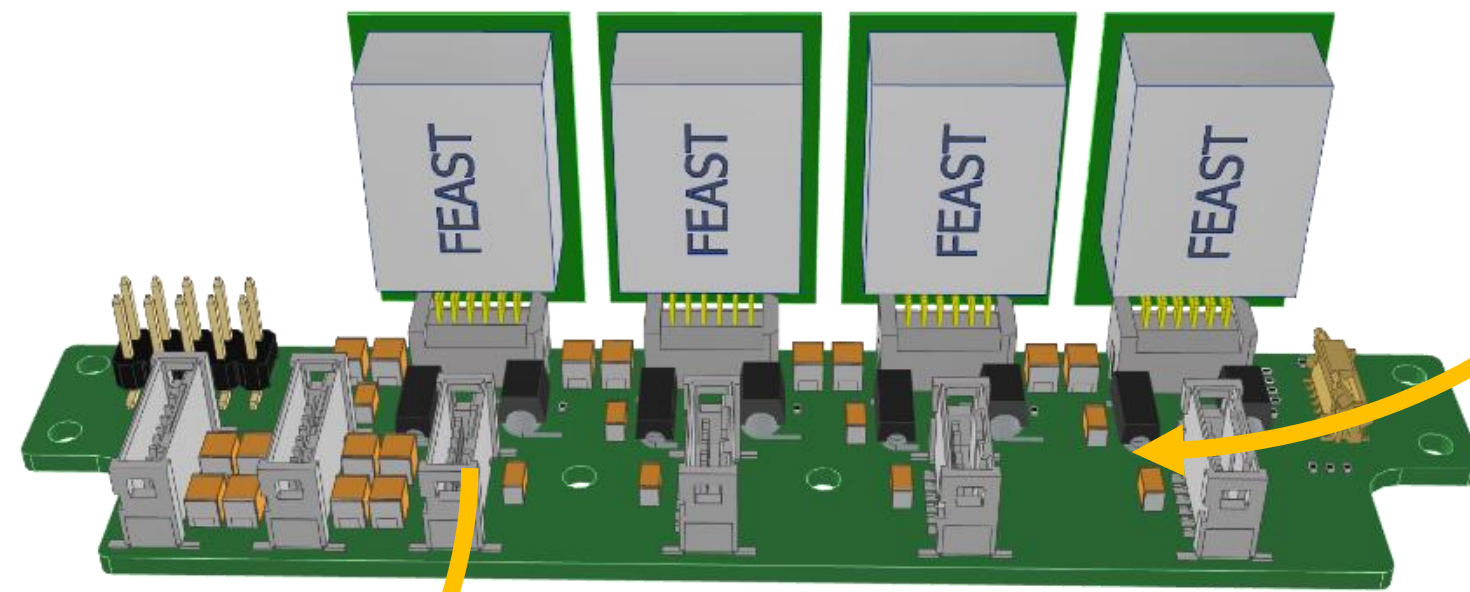


# MVD Powering System





# MVD Powering System



Power Supply  
(MVD Rack)

Air Vacuum

Detector

Beam

$\sim 10\text{ V}$

10 V

Top Bias

$\sim 9\text{ V}$

FEAST  
DC/DC

Sensor

1.8 V

VDA & VDD

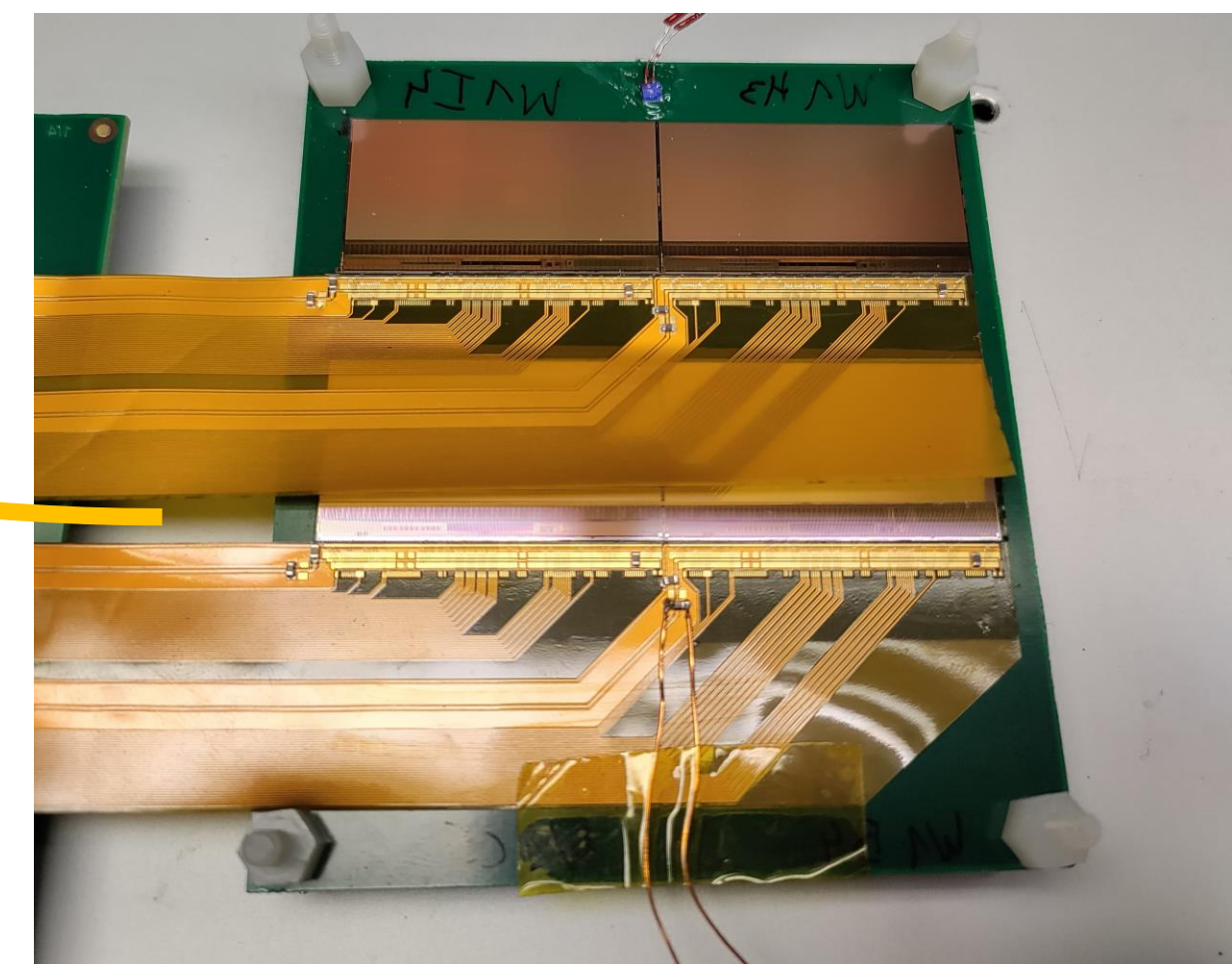
GND1

GND2

$\sim -3\text{ V}$

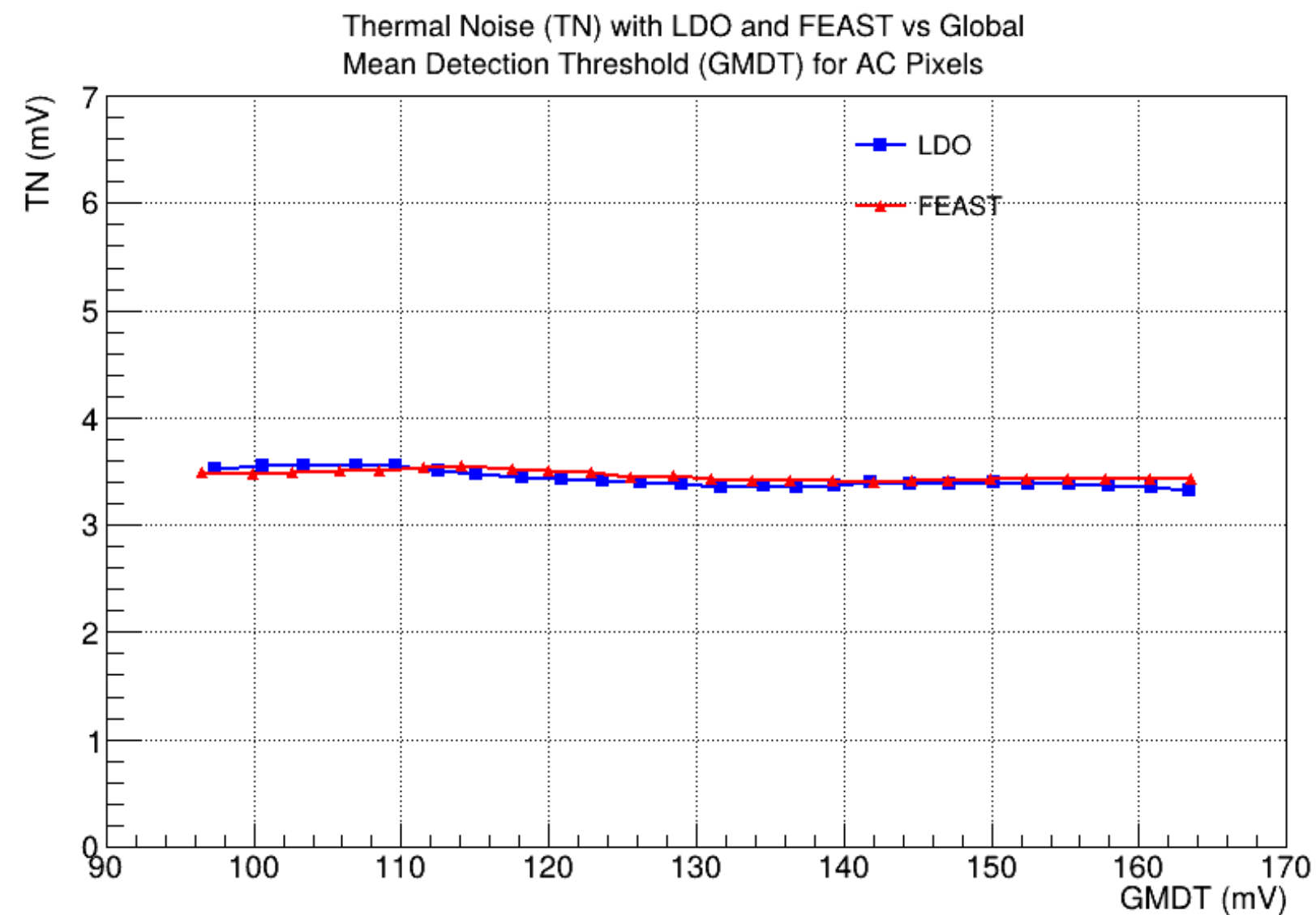
-3 V

Back Bias

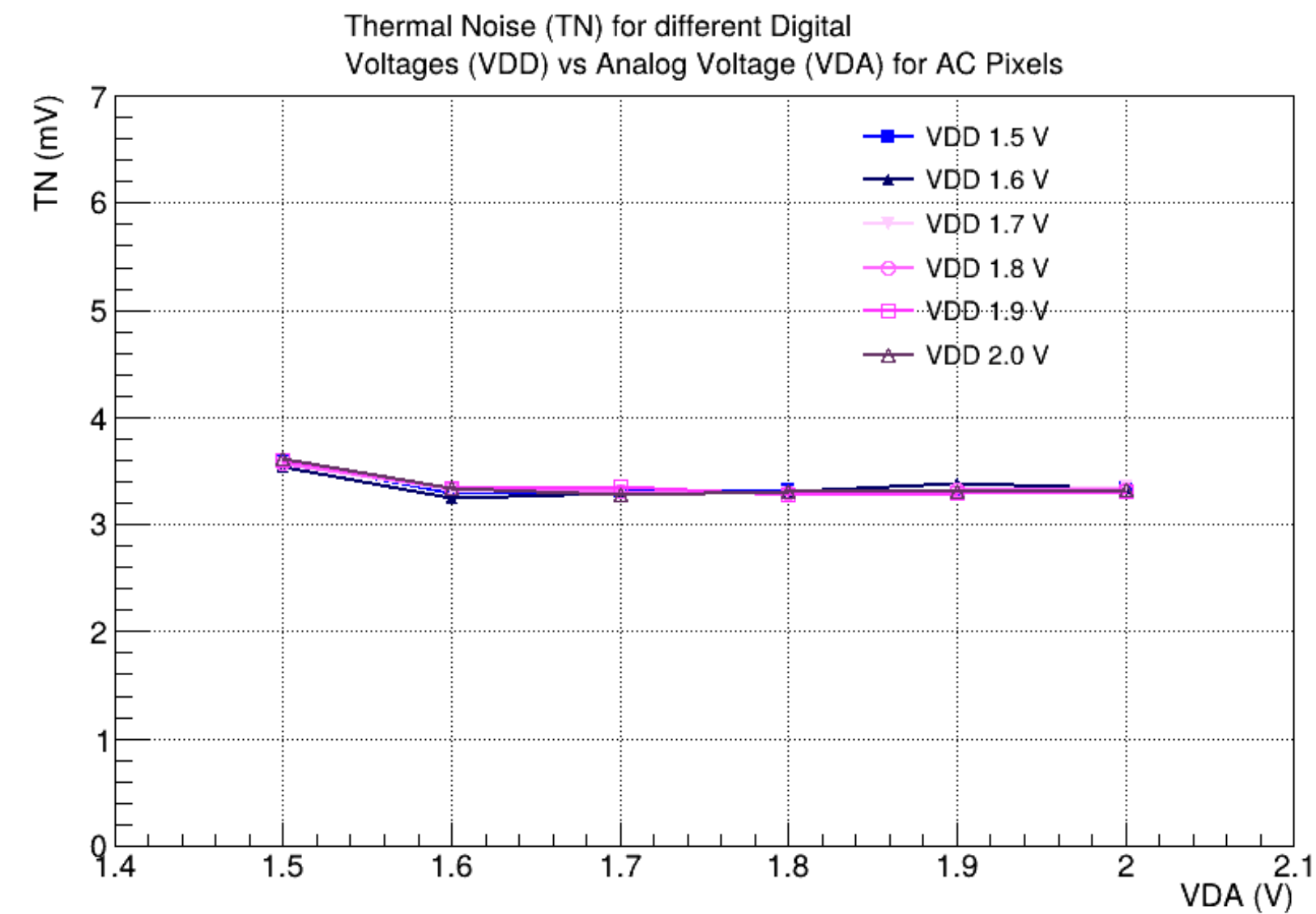




# Thermal Noise – Operation Scenarios



FEAST noise not picked up  
by sensor

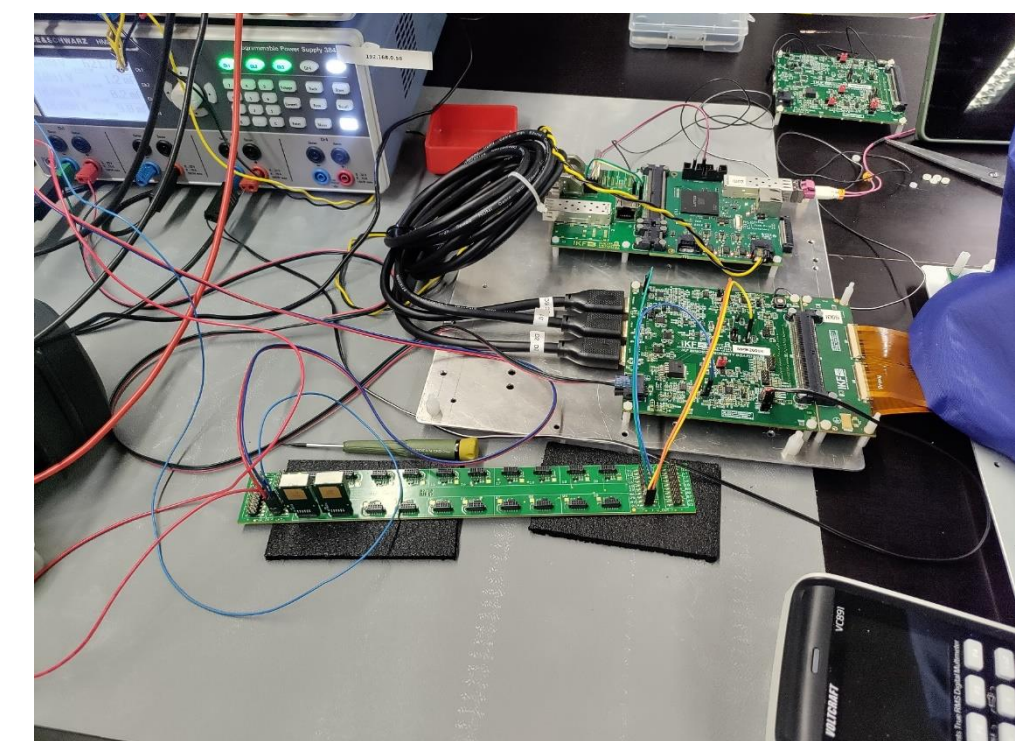


Stable over large operation  
voltage range

Cross powering not observed  
Power supply failure scenarios tested  
→ Fail-safety tested, implemented on FEB

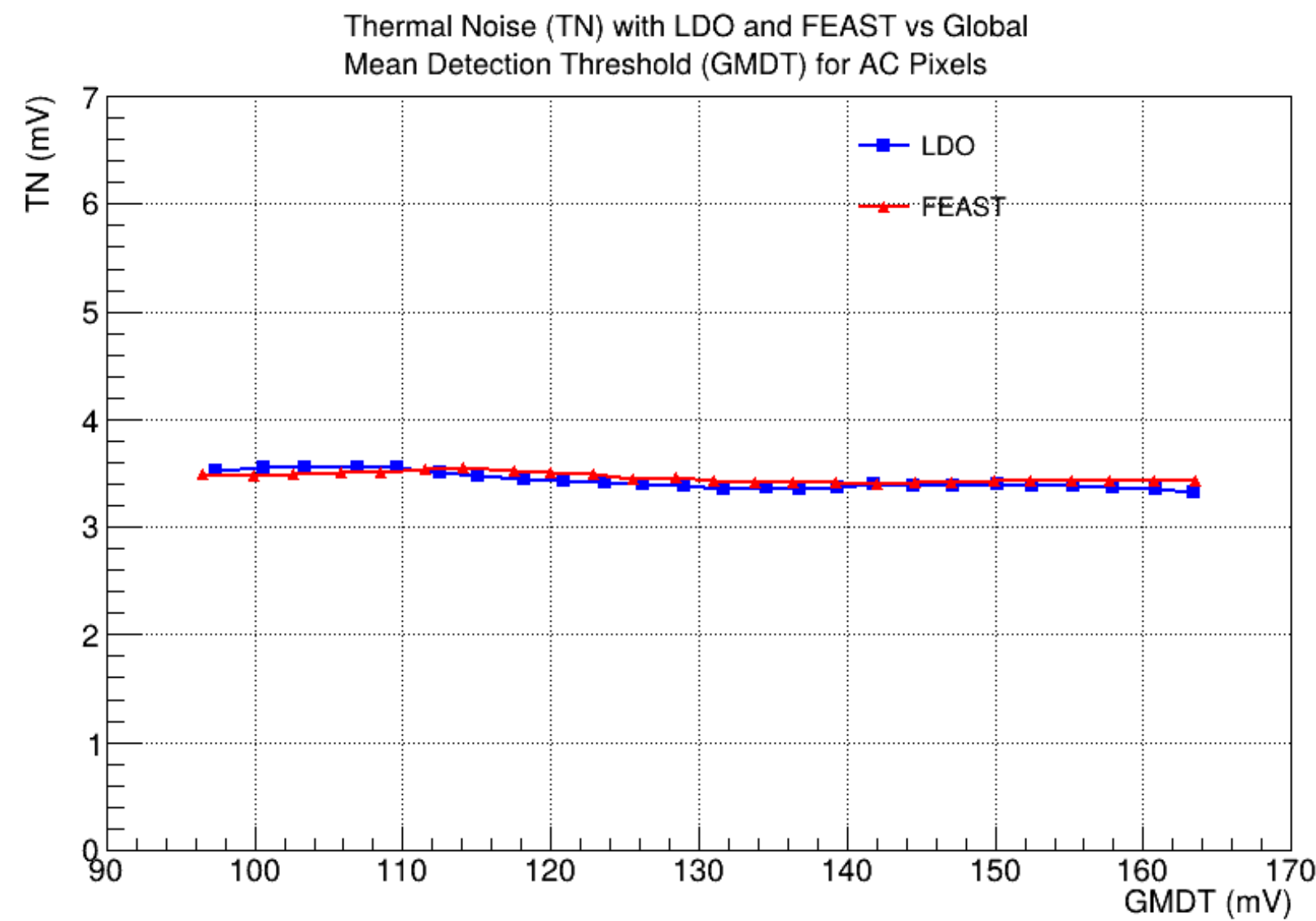
Ongoing: Occupancy fluctuation effects

Jan Michel, FM

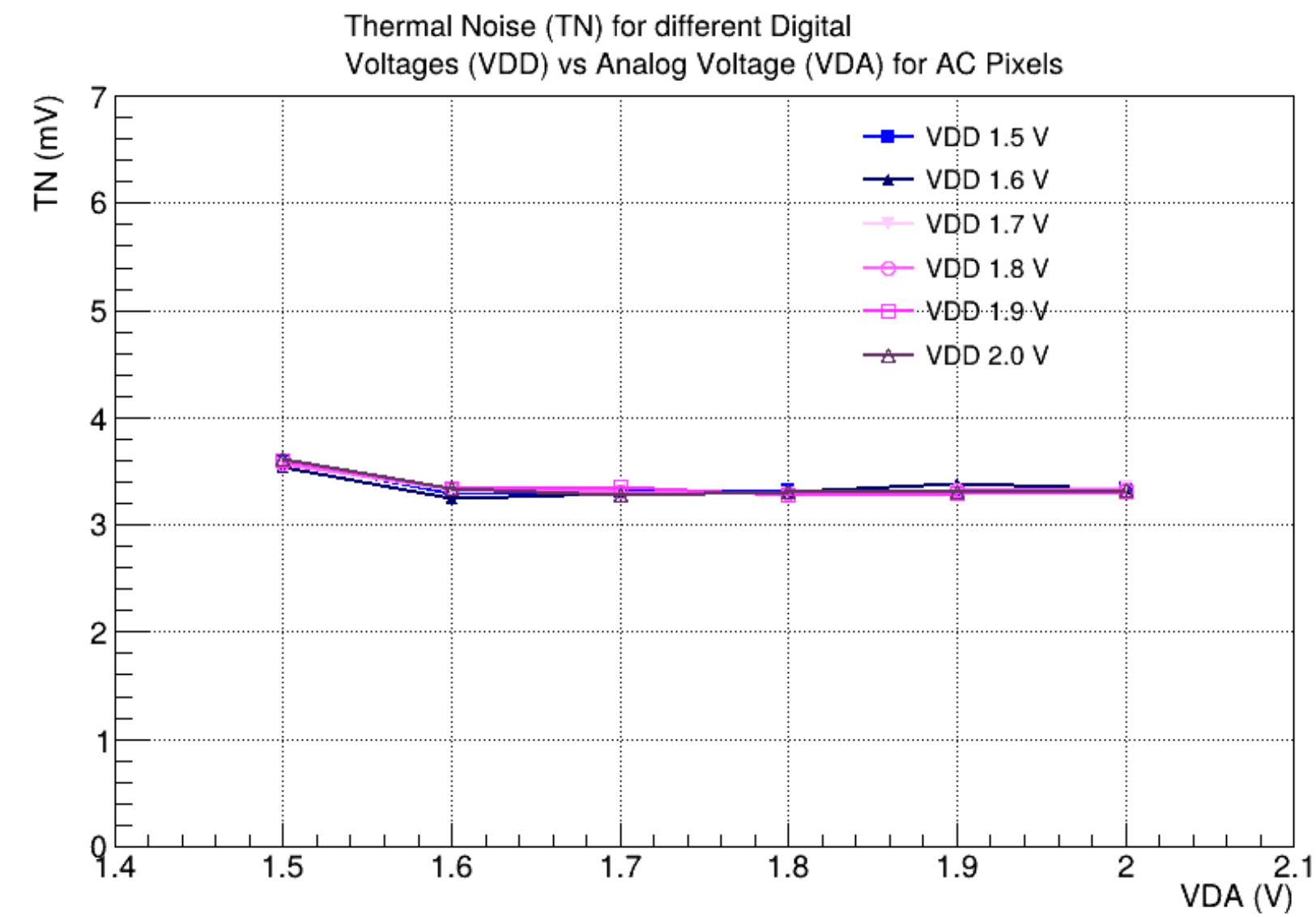




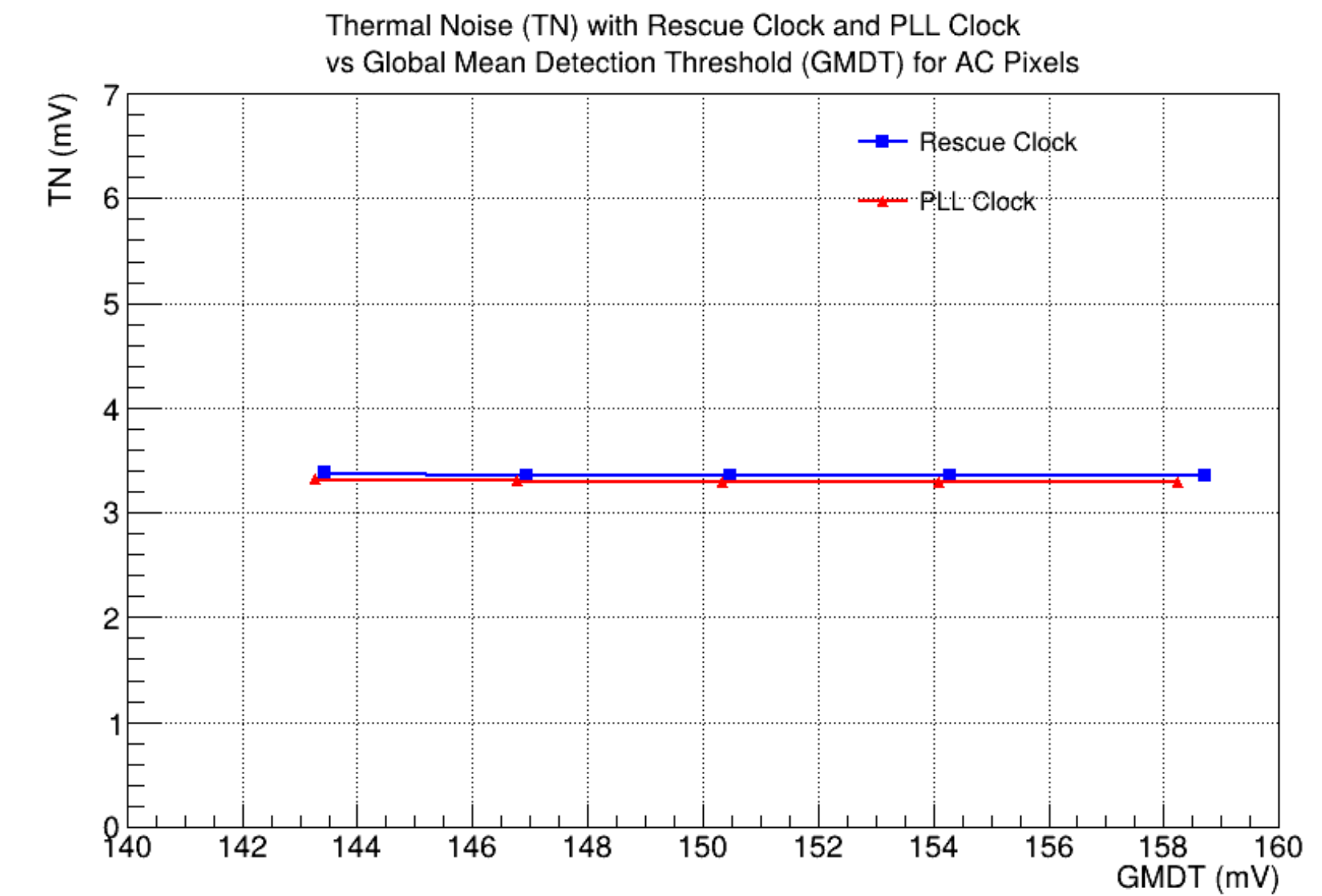
# Thermal Noise – Operation Scenarios



FEAST noise not picked up  
by sensor



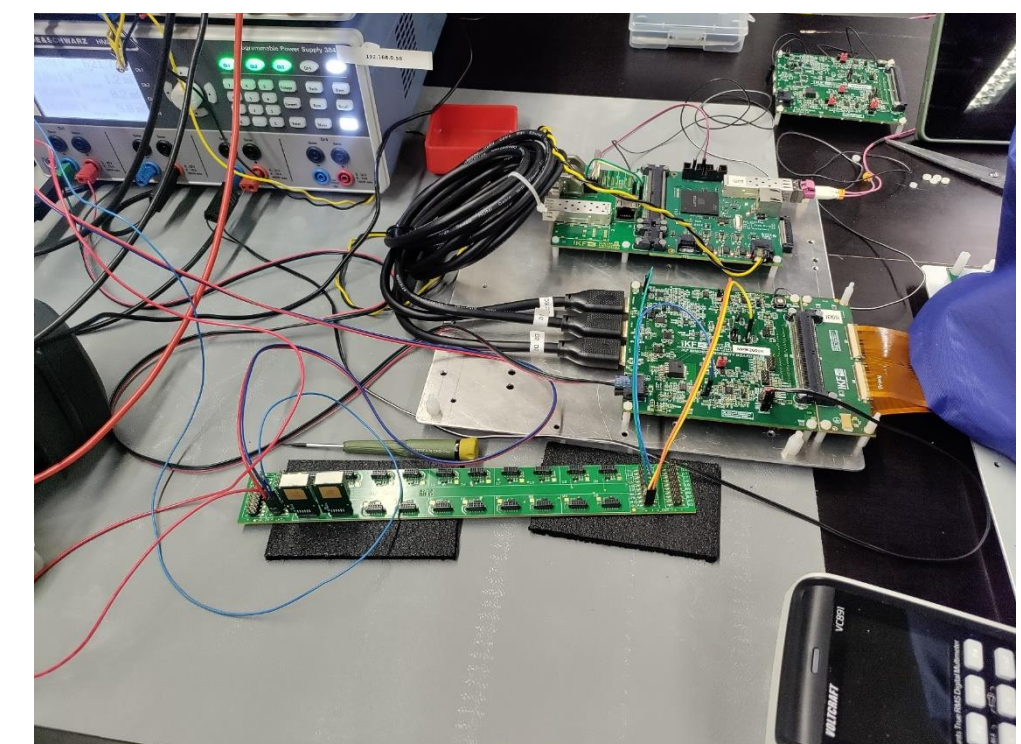
Stable over large operation  
voltage range



No noise pick-up from fast  
clock

Cross powering not observed  
Power supply failure scenarios tested  
→ Fail-safety tested, implemented on FEB

Ongoing: Occupancy fluctuation effects



Jan Michel, FM



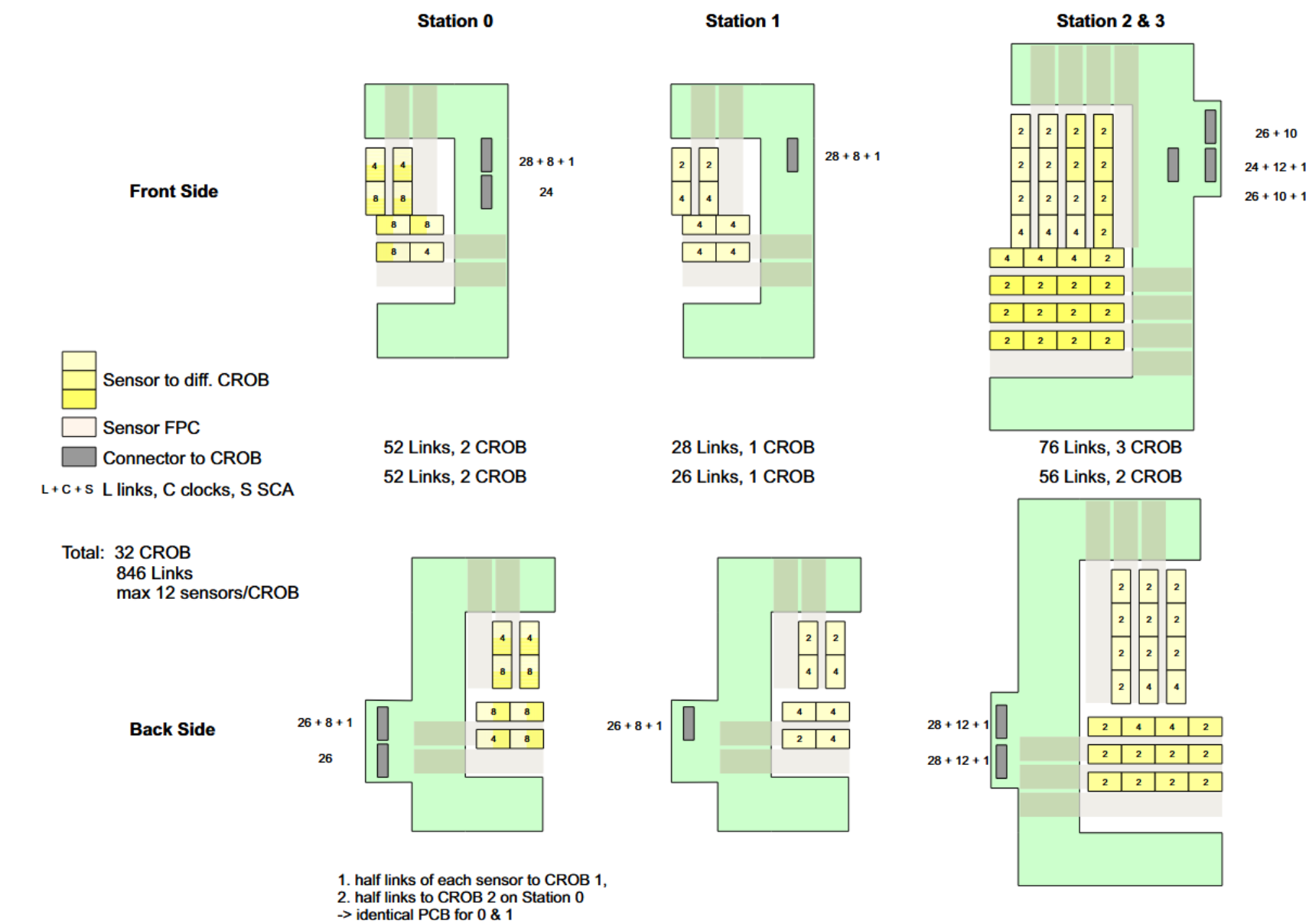
# Reading out the MVD

Sensor can run on 8, 4, 2, 1 320 Mbit/s data links

→ Optimize link layout w.r.t. data rate, bandwidth usage, e-links

→ Hard constraints: physics, buffer limitations (sensor), cluster size, space

→ Soft constraints: data loss, safety margins, use of resources, spatial precision





# Reading out the MVD

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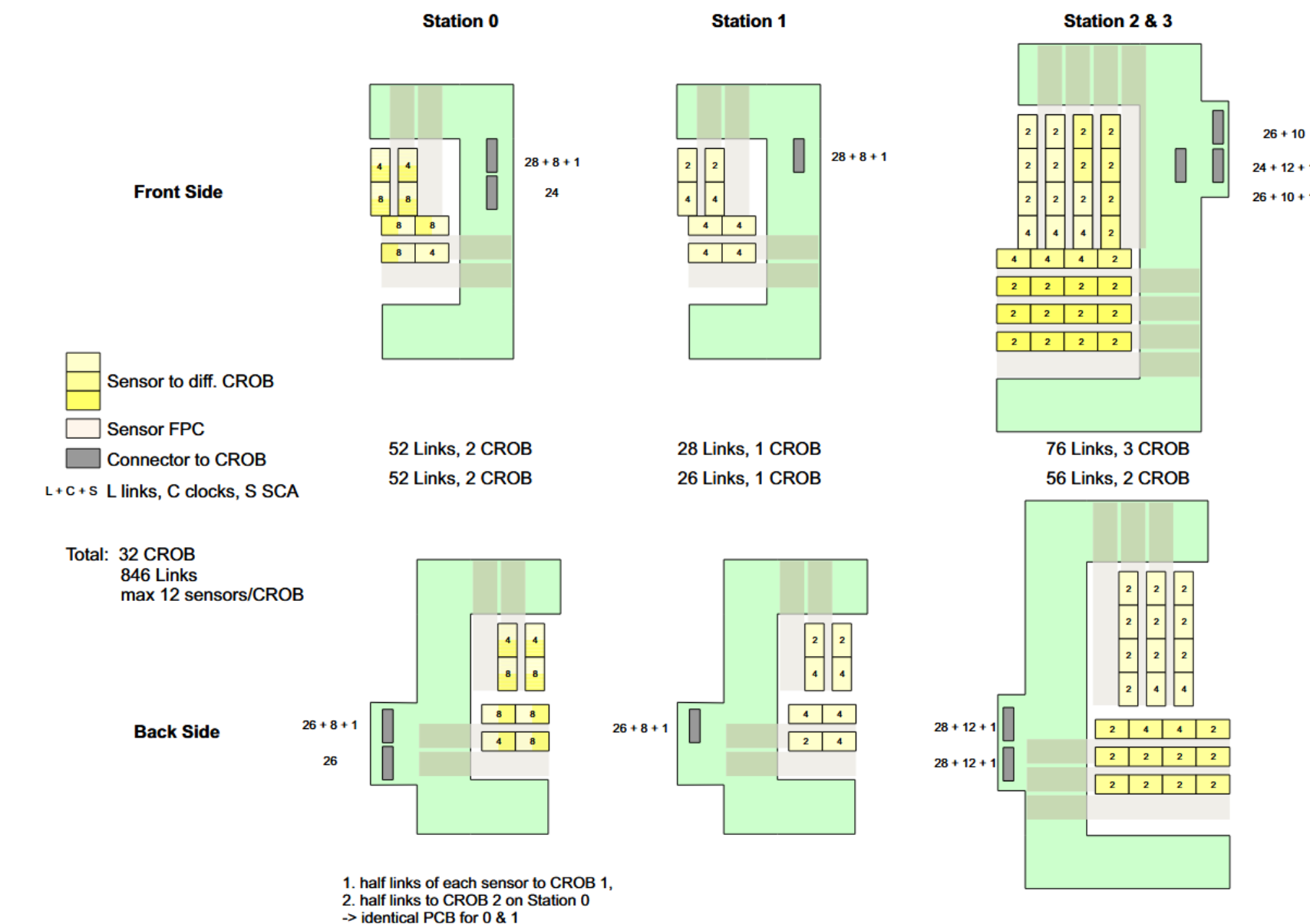
→ Soft constraints: data loss, safety margins, use of resources, spatial precision

Likely MVD sensor: p-stop 50  $\mu\text{m}$ , also at EOL doses

→ 4 (5-6)  $\mu\text{m}$  spatial precision,  $> 99.9\%$  efficiency,  $< 10^{-9}$  /pixel/frame FHR

→  $\sim 0.03\%$   $X_0$  additional material budget wrt. 25  $\mu\text{m}$  Epi

3.0 – 3.3 GB/s avg.,  $\sim 8$  GB/s peak





# Reading out the MVD

Sensor can run on 8, 4, 2, 1 320 Mbit/s data links

→ Optimize link layout w.r.t. data rate, bandwidth usage, e-links

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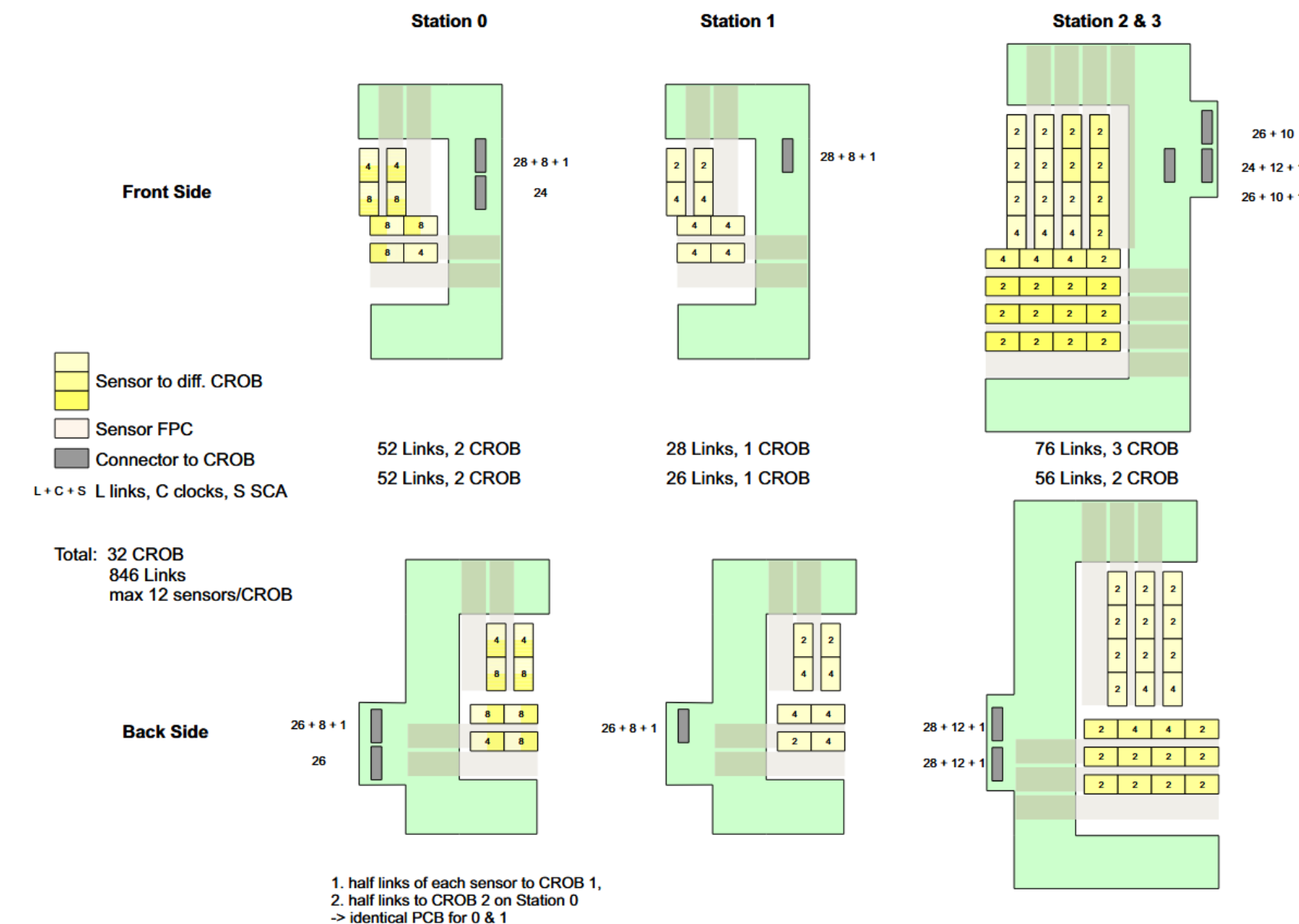
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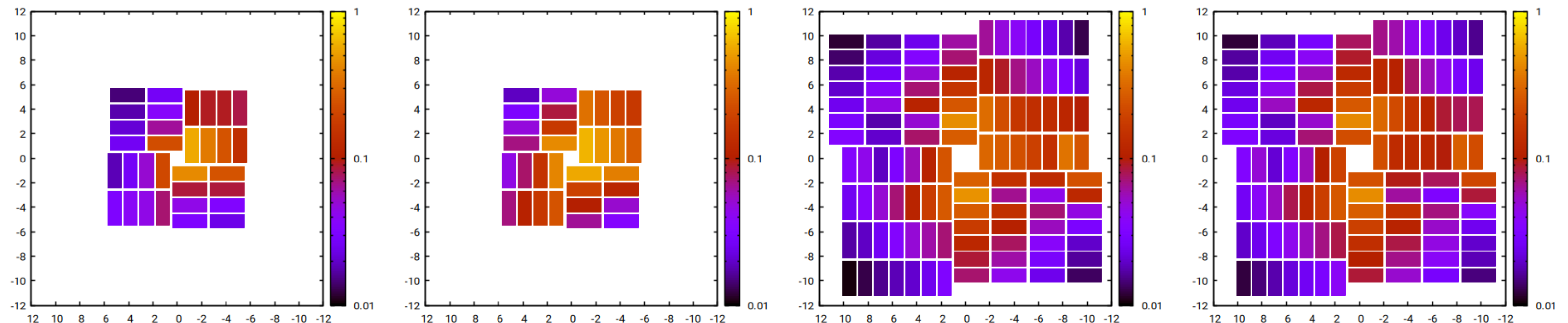
→ 4 (5-6)  $\mu\text{m}$  spatial precision,  $> 99.9\%$  efficiency,  $< 10^{-9}$  /pixel/frame FHR

→  $\sim 0.03\%$   $X_0$  additional material budget wrt. 25  $\mu\text{m}$  Epi

3.0 – 3.3 GB/s avg.,  $\sim 8$  GB/s peak



Bandwidth usage, optimized links/sensor, 100% field, geom 20c TR, 30 MHz beam  
Au+Au 12 AGeV, 0.66% minimum bias interactions, 0.66% central interactions (w/  $\delta$ )

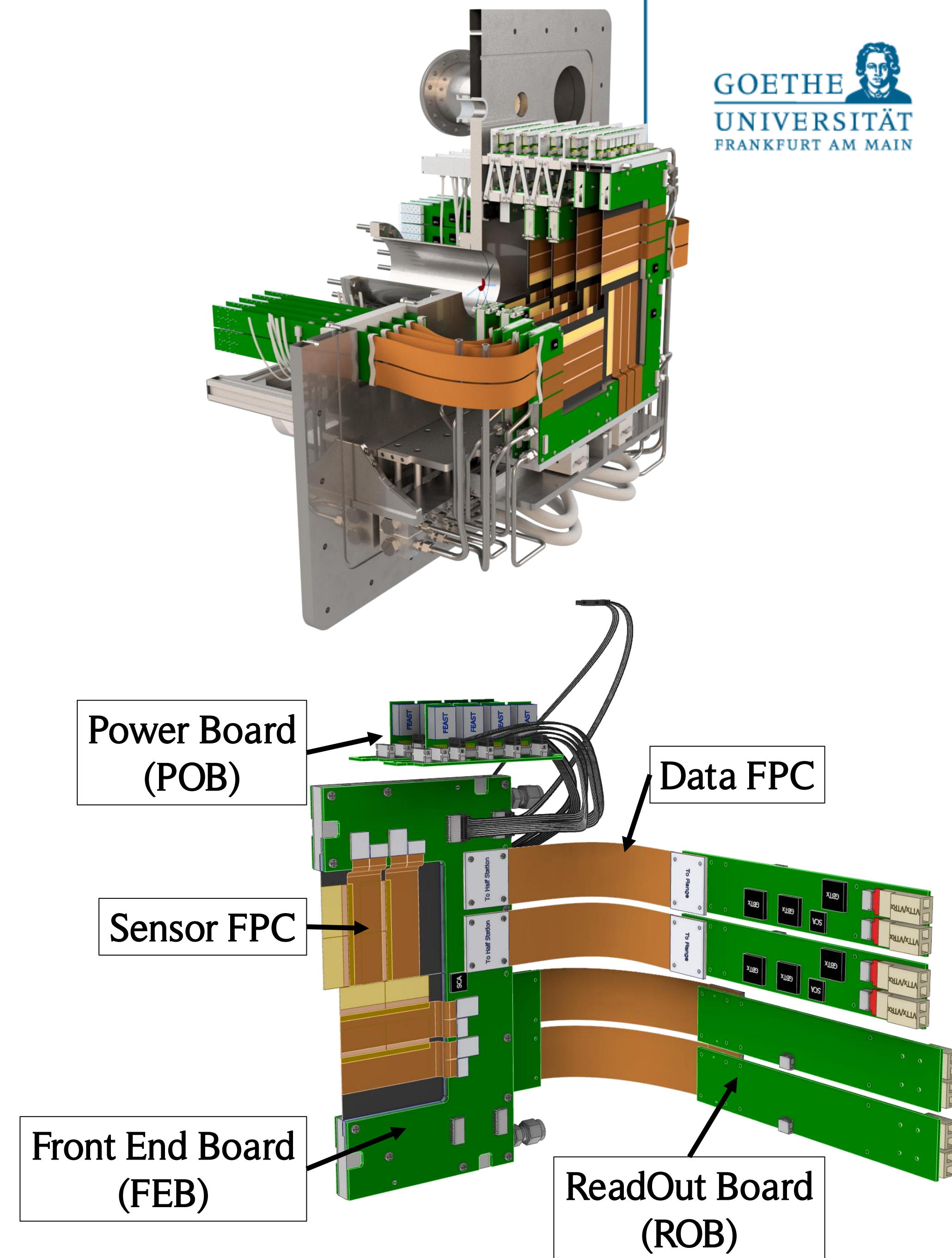




# Towards the MVD Electronics

## Requirements

- Space constraints
- Symmetries (sensors, FEBs, power, cooling)
- Galvanic separation





# Towards the MVD Electronics

## Requirements

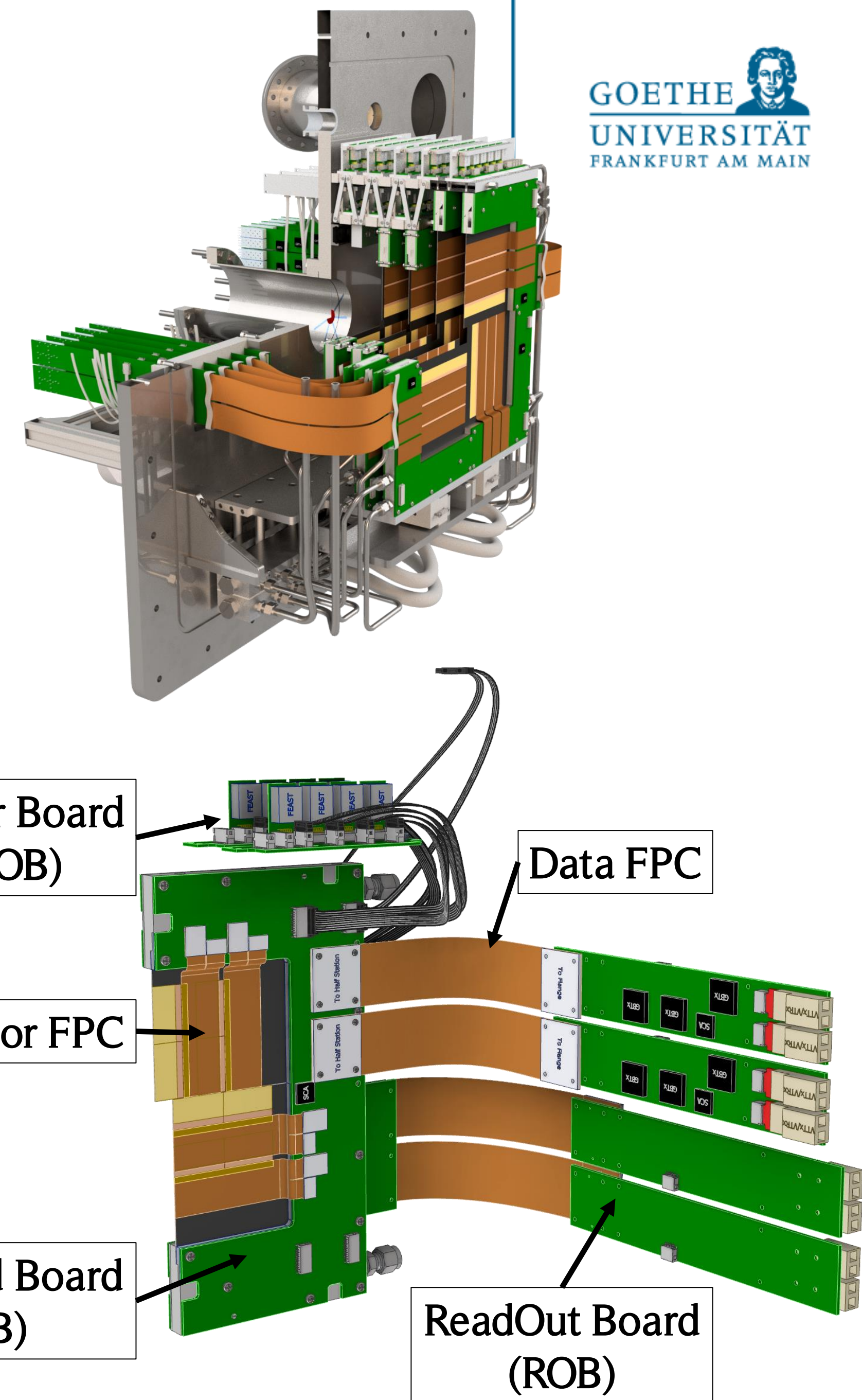
- Space constraints
- Symmetries (sensors, FEBs, power, cooling)
- Galvanic separation

## Simplicity / Modularity

- Common ROB with STS
- Minimize number of different components
- Powering scheme, data link distribution, component placement, ...

See also Jörg's contribution:

<https://indico.gsi.de/event/20881/contributions/92716/>





# Towards the MVD Electronics

## Requirements

- Space constraints
- Symmetries (sensors, FEBs, power, cooling)
- Galvanic separation

## Simplicity / Modularity

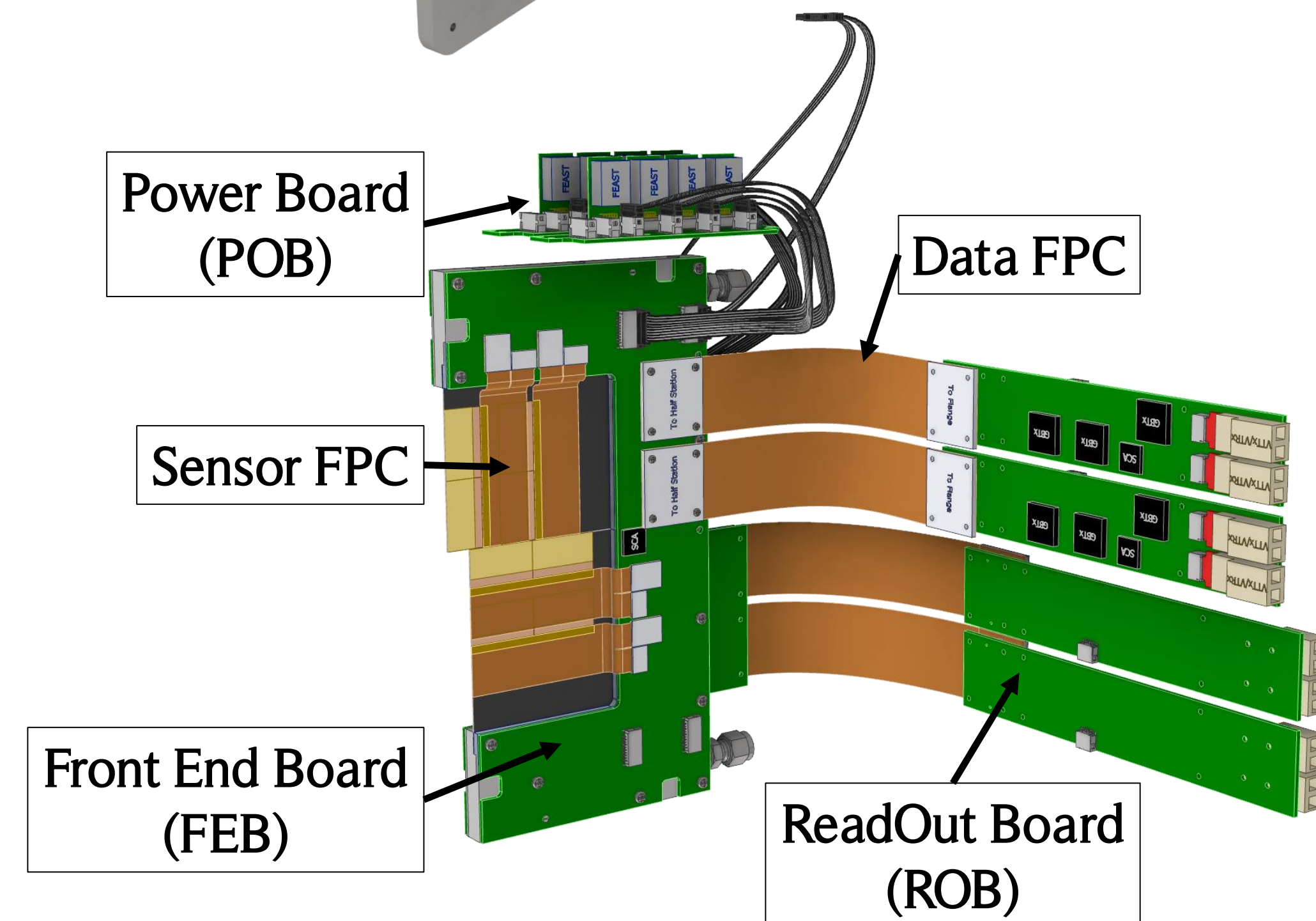
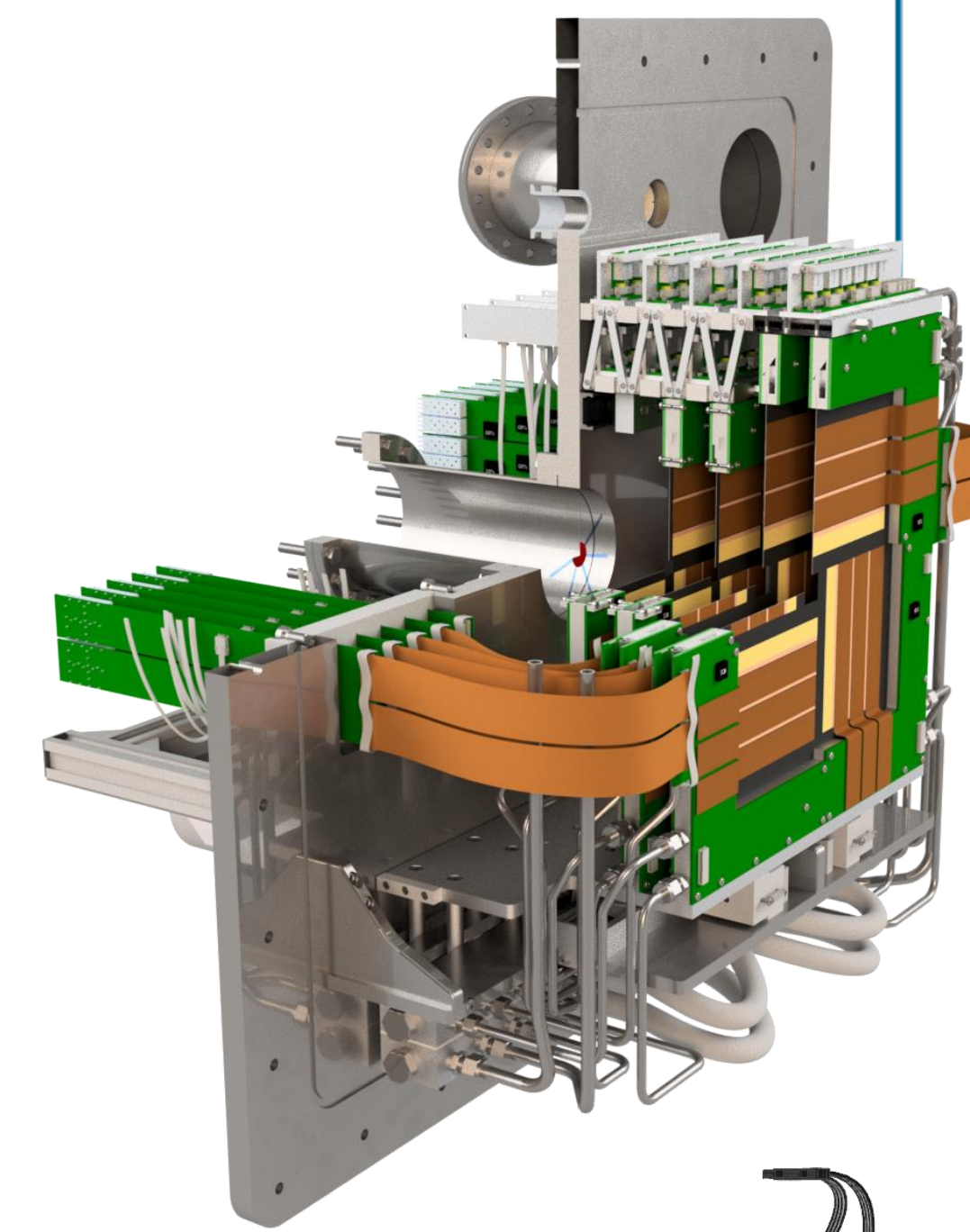
- Common ROB with STS
- Minimize number of different components
- Powering scheme, data link distribution, component placement, ...

## Pre-production for front-side geo “b”, MIMOSIS-2.1

- Sensor FPCs adapted for MIMOSIS-3
- Likely no modifications FEB, POB, Data FPC

See also Jörg's contribution:

<https://indico.gsi.de/event/20881/contributions/92716/>



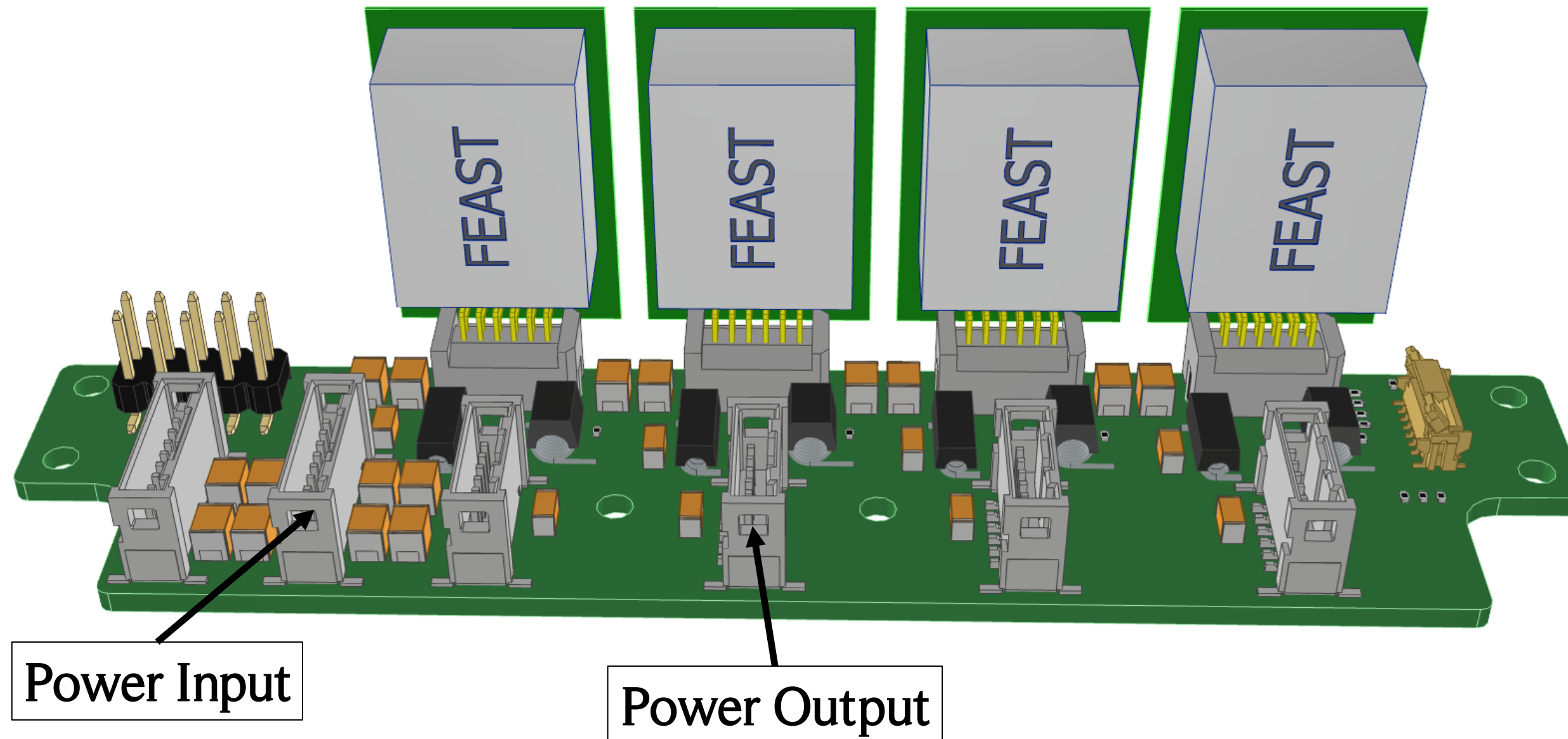
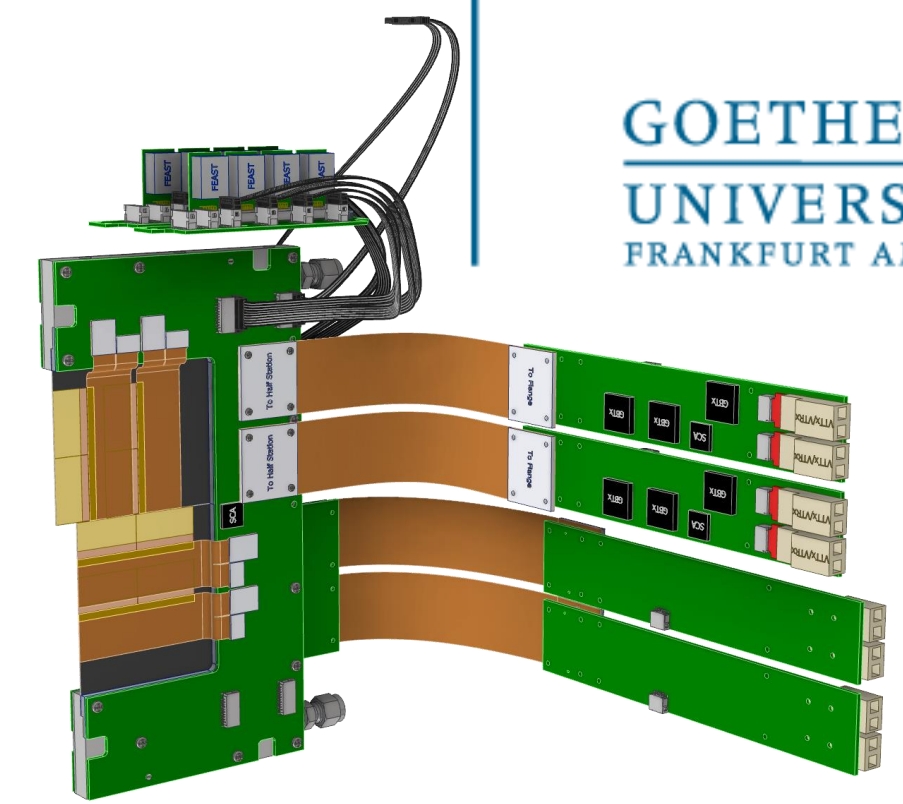
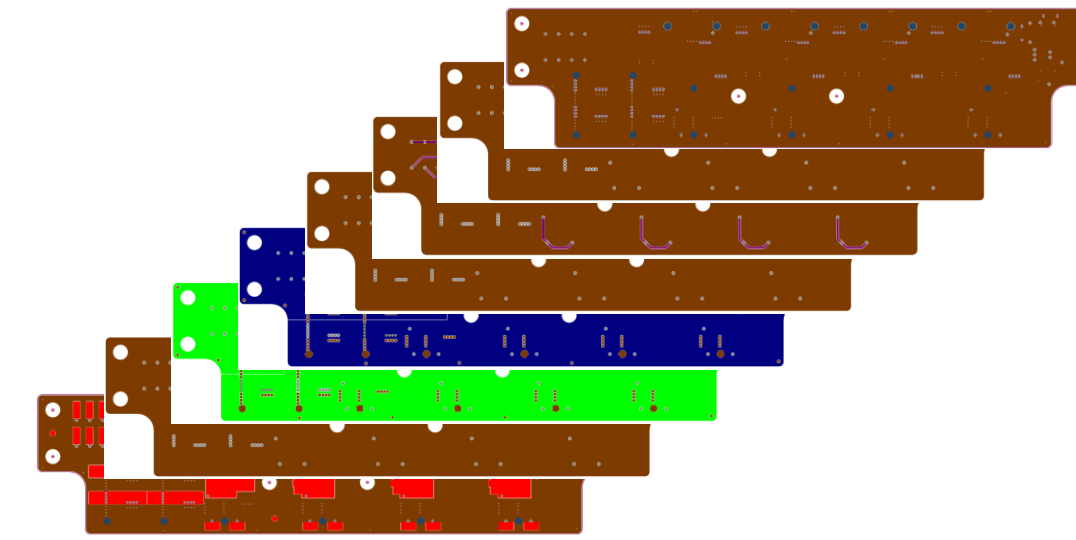


# Power Board (POB)

8-layer PCB for powering geo “b” (FEASTMP DC/DC)

No further modifications for MIMOSIS-3 expected

→ Geo “c” and RPOB

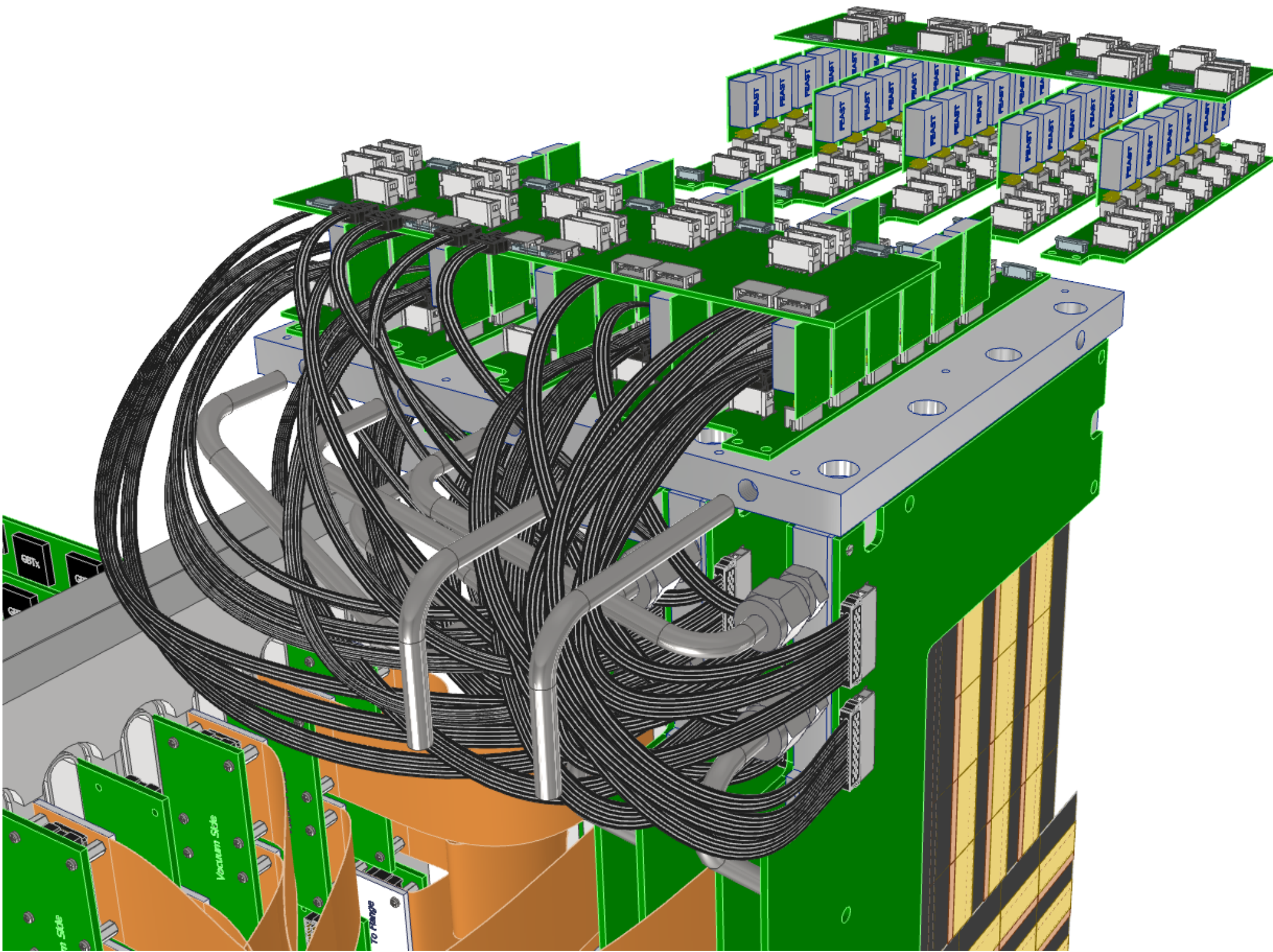
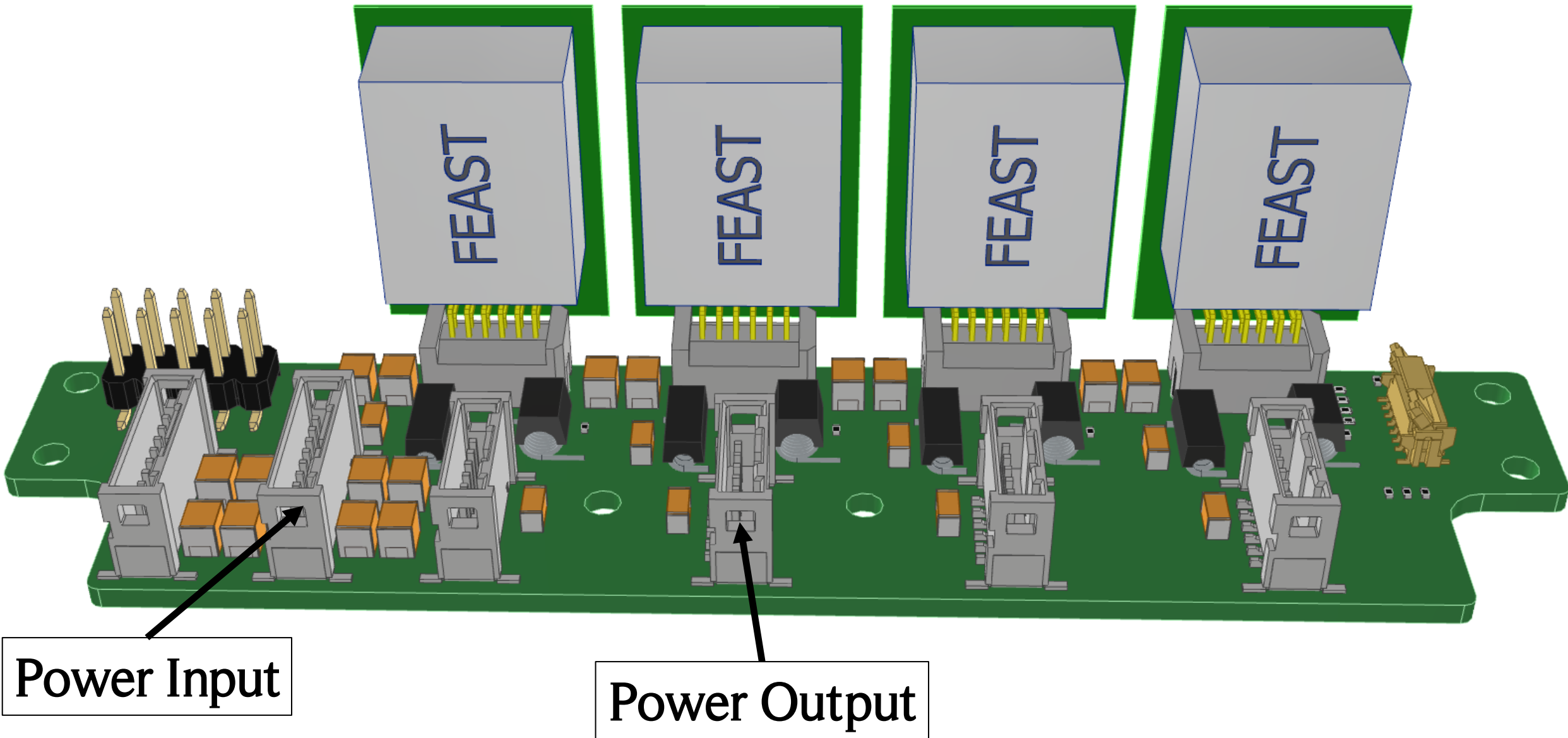
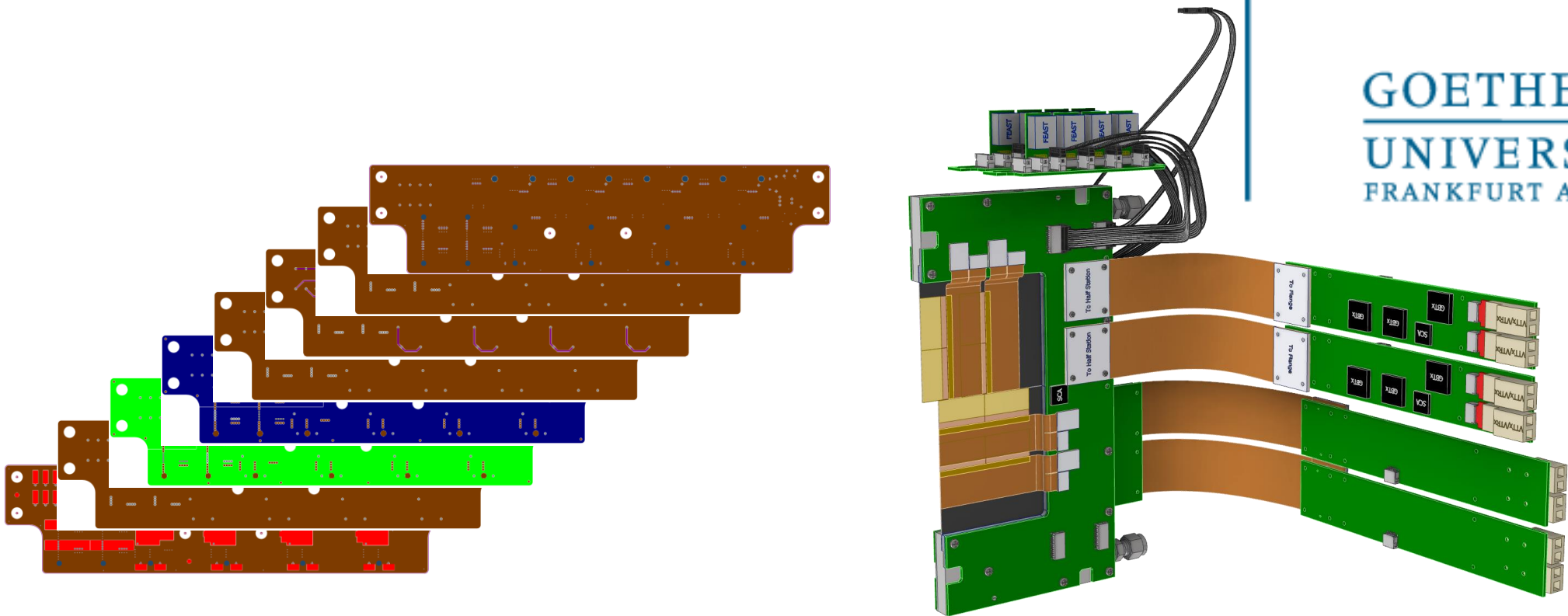


Jan Michel, FM



# Power Board (POB)

8-layer PCB for powering geo “b” (FEASTMP DC/DC)  
No further modifications for MIMOSIS-3 expected  
→ Geo “c” and RPOB



Jan Michel, FM

Top View of DC/DC placement on lower Top Plate (Half-Station)				
	1 (Innermost)	2	3	4 (Outermost)
Fin 1 (upstream)	D0B→1	D0F→2	A0F→1	D0F→1
Fin 2	A0B→2	D0B→2	A1F→1	D1F→1
Fin 3 (downstream)	A1B→2	D1B→2	D1B→1	D1F→2

Top View of DC/DC placement on upper Top Plate (Half-Station)						
	1 (Innermost)	2	3	4	5	6 (Outermost)
Fin 1 (upstream)	A2F→2	D2F→2	D2F→2	A2F→1	D2F→1	D2F→1
Fin 2	A2B→2	D2B→2	D2B→2	A2B→1	D2B→1	D2B→1
Fin 3	SCA→PDR		D2F→3	D2F→3	D3F→3	D3F→3
Fin 4	A3F→2	D3F→2	D3F→2	A3F→1	D3F→1	D3F→1
Fin 5 (downstream)	A3B→2	D3B→2	D3B→2	A3B→1	D3B→1	D3B→1

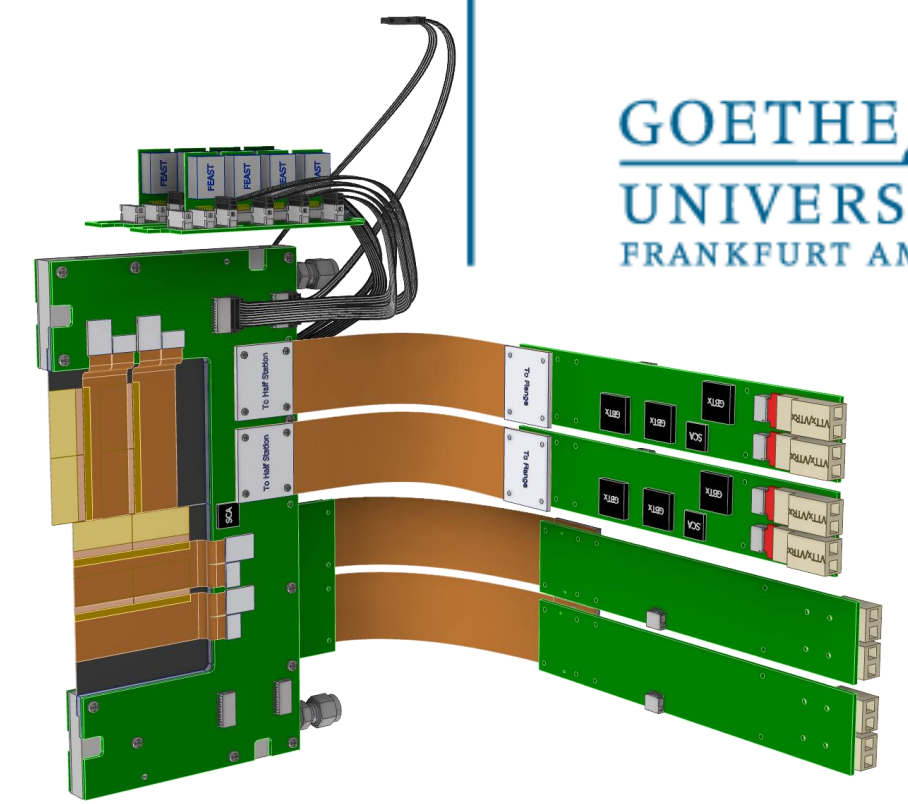


# Front End Board (FEB)

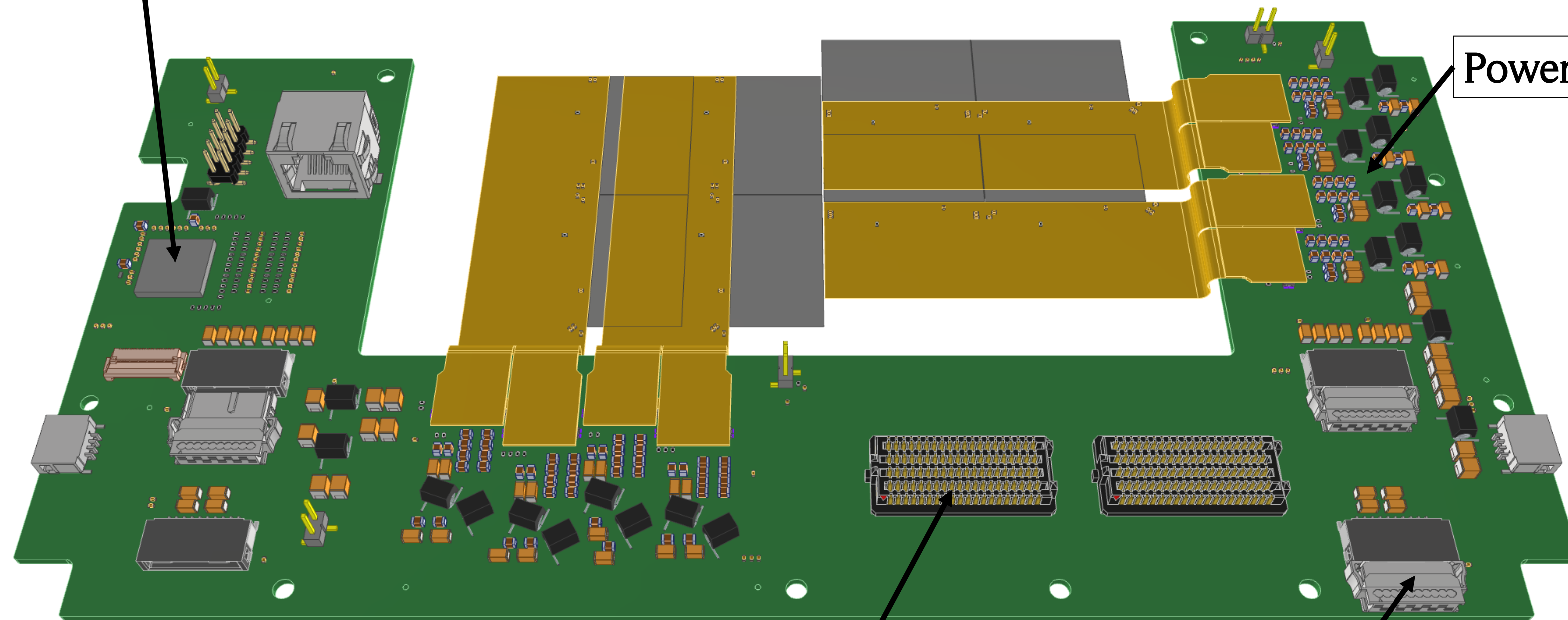
8-layer PCB for front-side geo “b”

No further modifications for MIMOSIS-3 expected

→ Back-side geo “b” and front- & back-side geo “c”



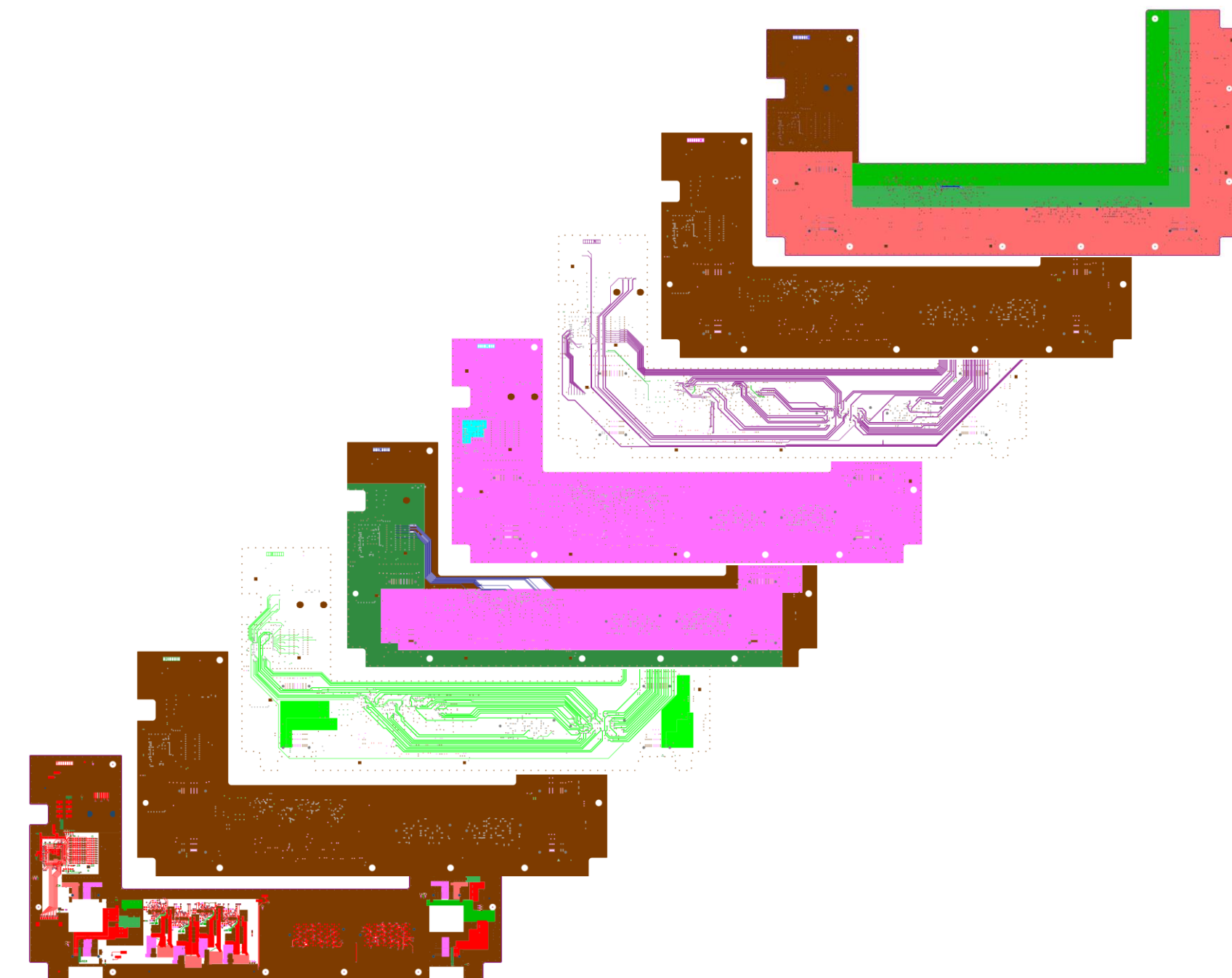
Slow Control,  
Monitoring (GBT-SCA)



Power Filtering

Data, Clock

Power Input





# Sensor FPC (2nd iteration)

Electrical connection for 2 sensors, front-side geo “b”

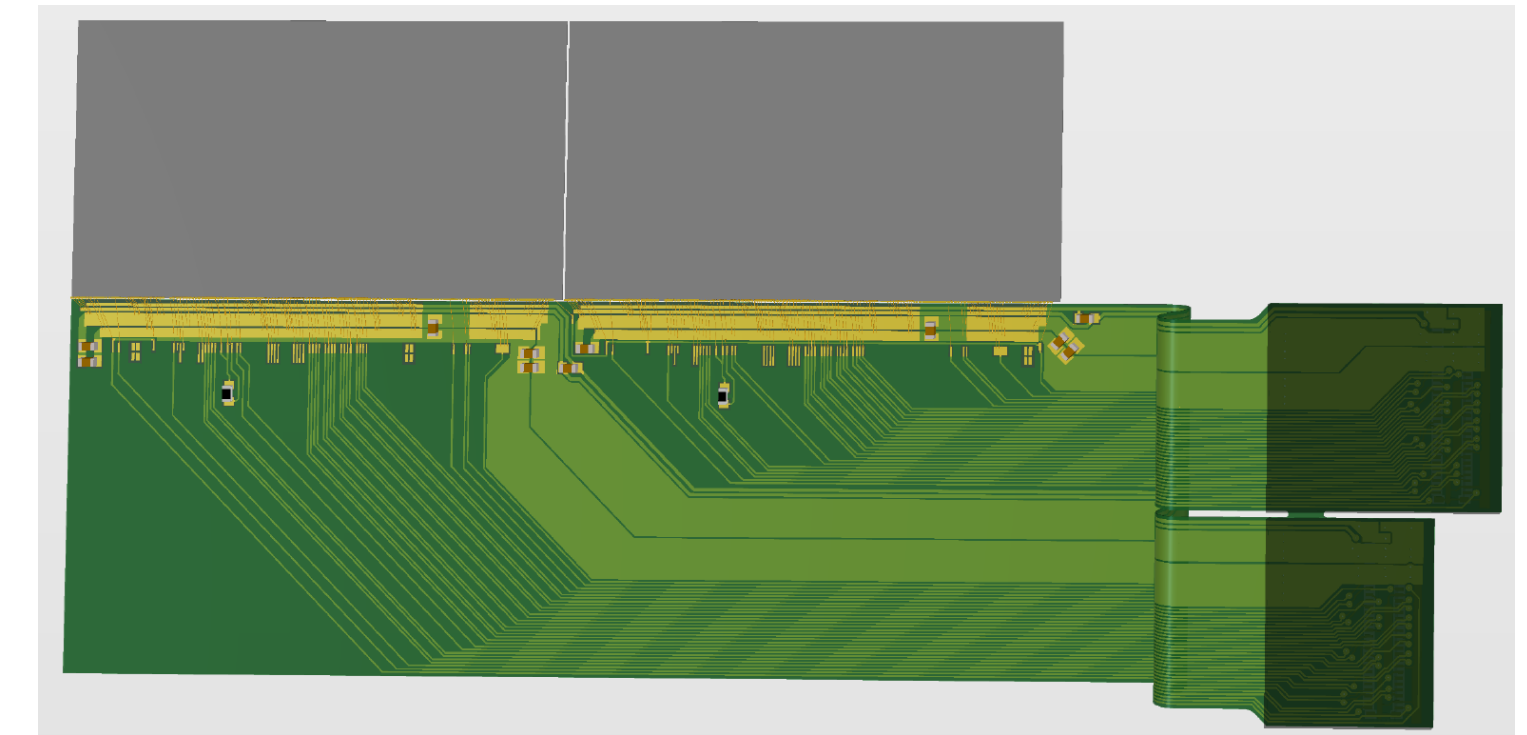
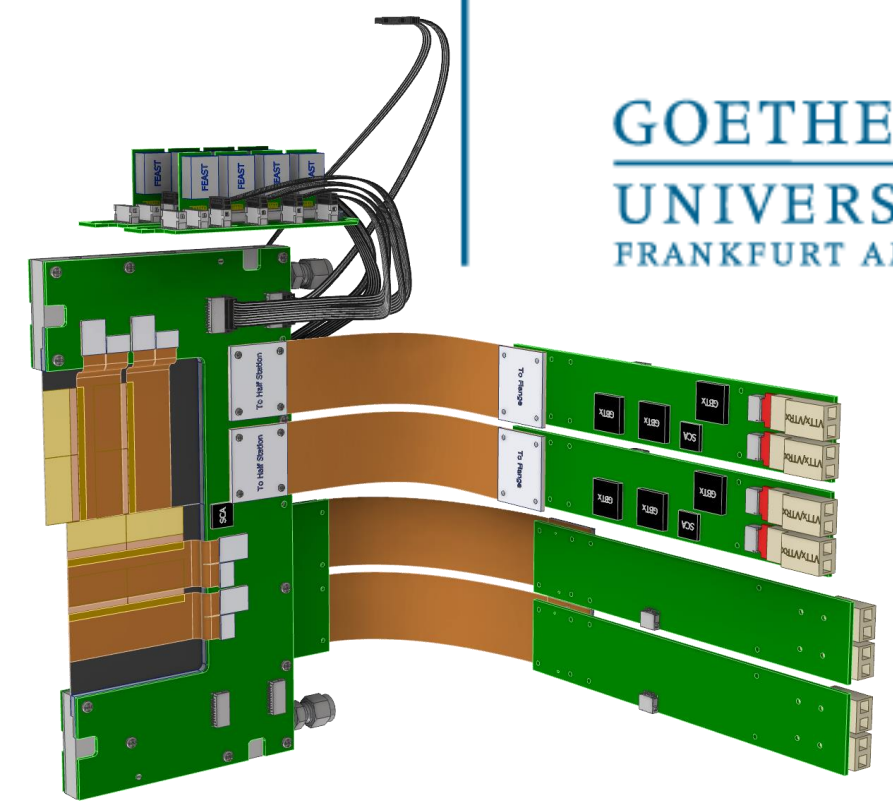
Only 27/104 functionality (non-biasing) pads routed

Two further iterations expected

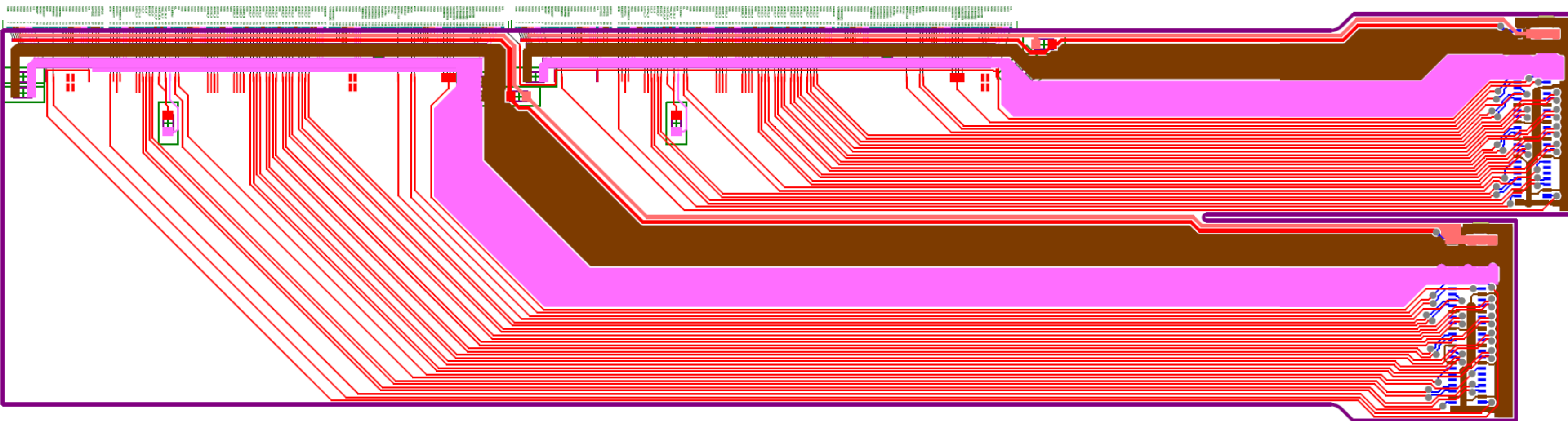
→ Further reduction of lines (MIMOSIS-3)

→ Material budget (ILFA)

→ Back-side geo “b”, front- & back-side geo “c”



Jan Michel, FM





# Sensor FPC (2nd iteration)

Electrical connection for 2 sensors, front-side geo “b”

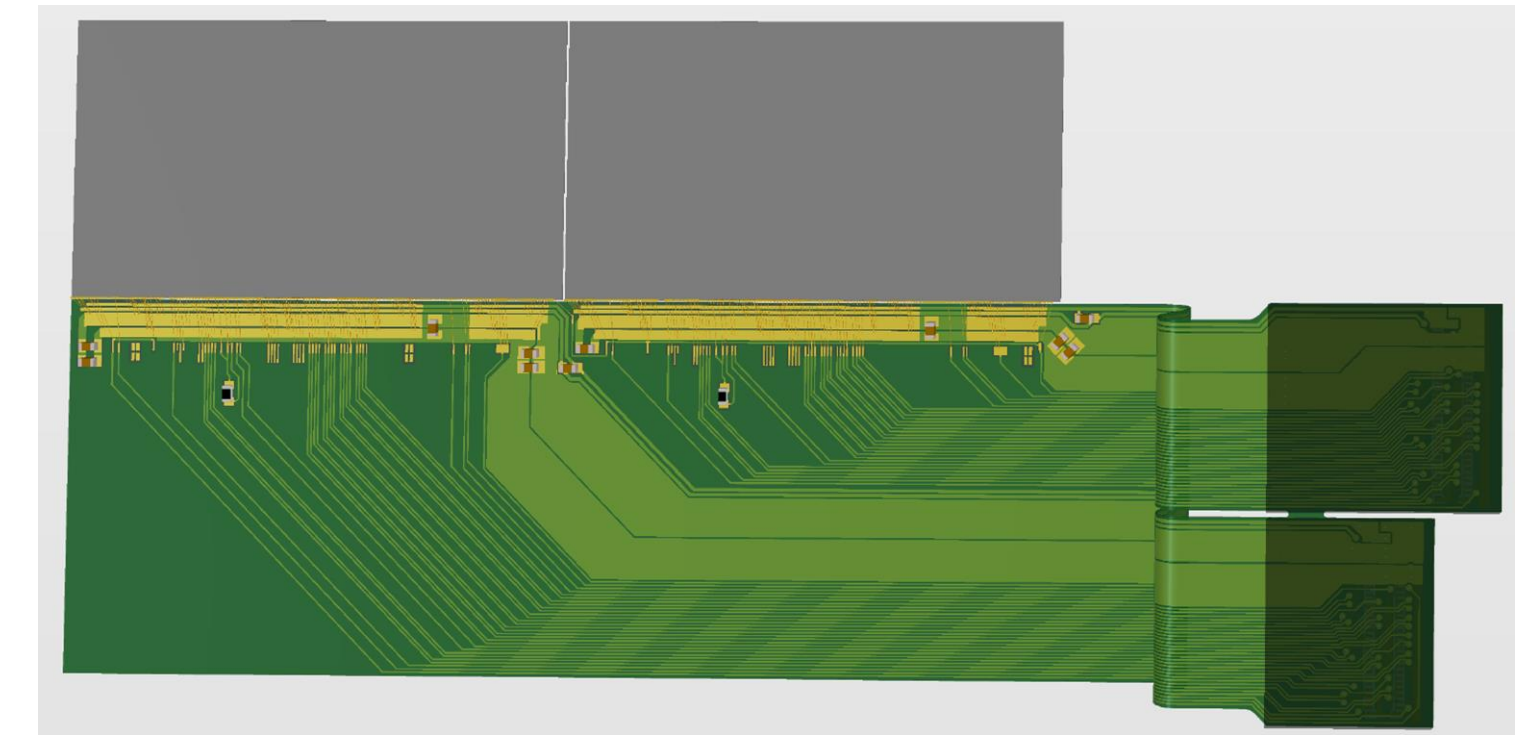
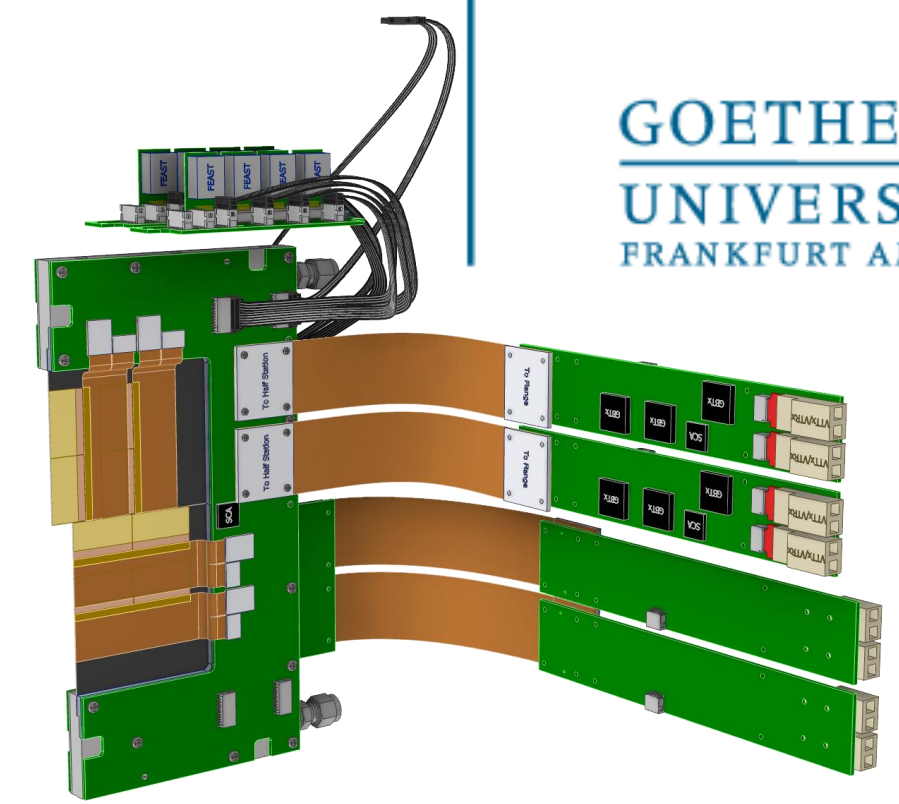
Only 27/104 functionality (non-biasing) pads routed

Two further iterations expected

→ Further reduction of lines (MIMOSIS-3)

→ Material budget (ILFA)

→ Back-side geo “b”, front- & back-side geo “c”



Jan Michel, FM

Kapton dummy with features for integration





# Data FPC

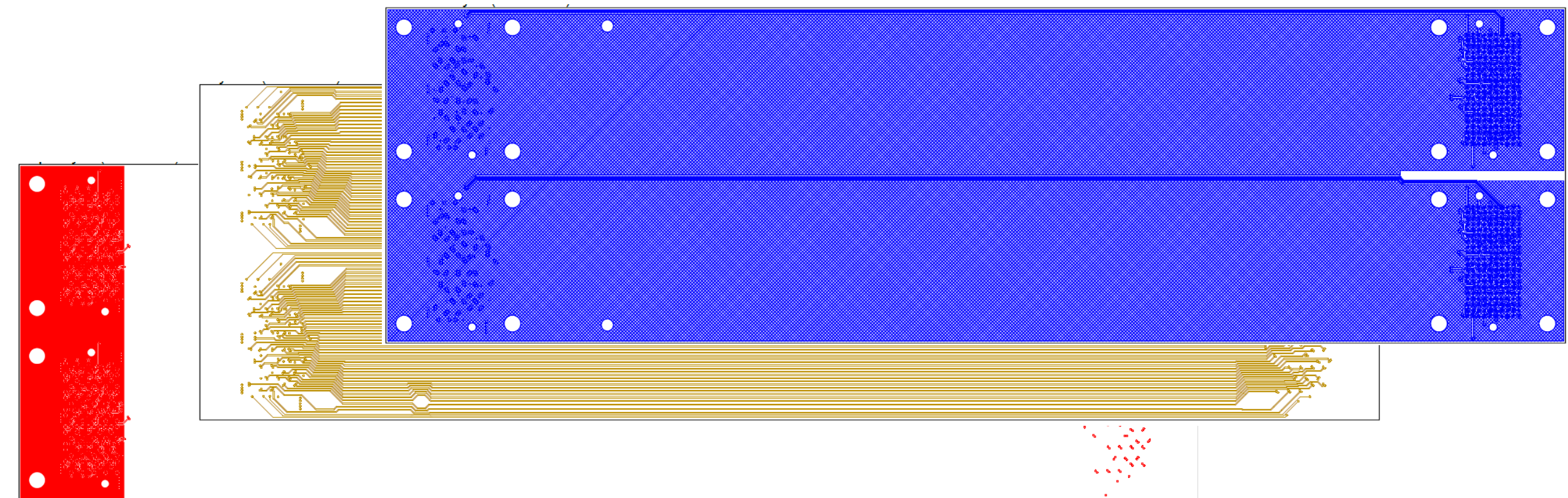
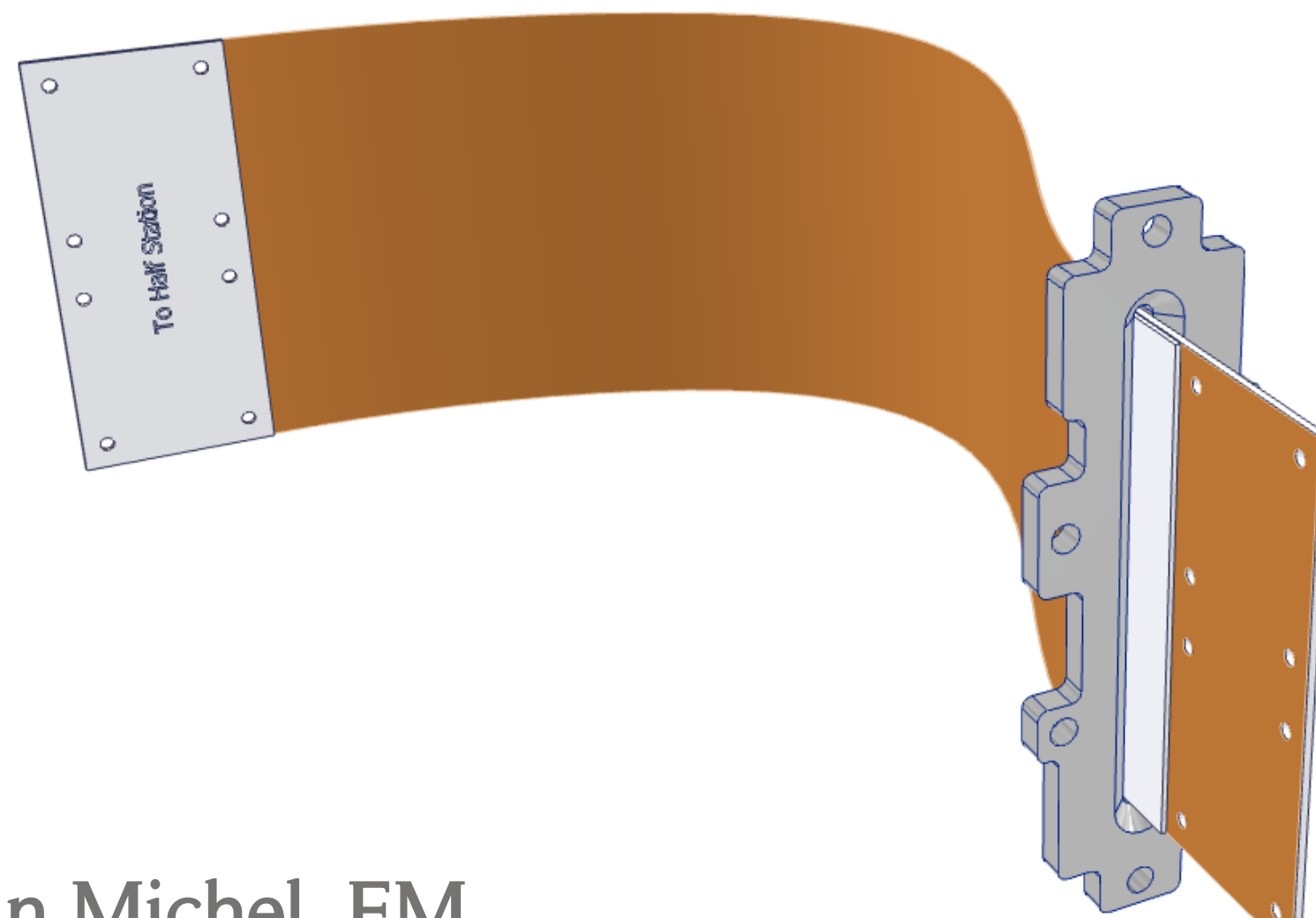
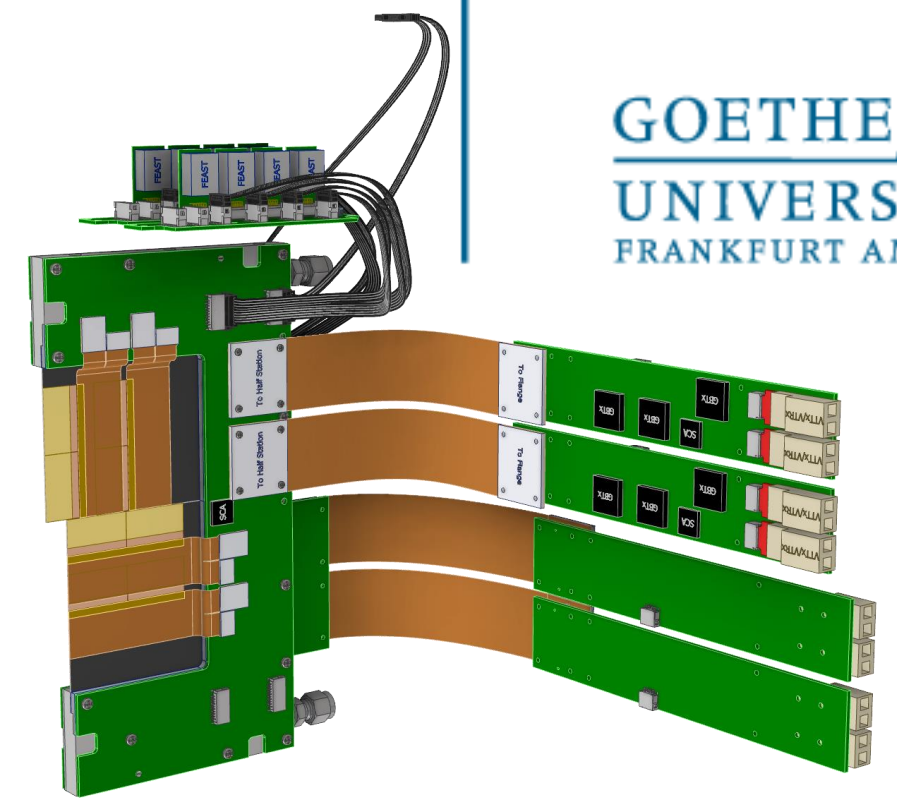
3-layer FPC for geo “b” connect CROBs outside vacuum

→ Custom FPC-based feedthrough for ~5000 lines for data, clock

→ Needs parallel development with feedthrough flange

No further modifications for MIMOSIS-3 expected

→ geo “c”

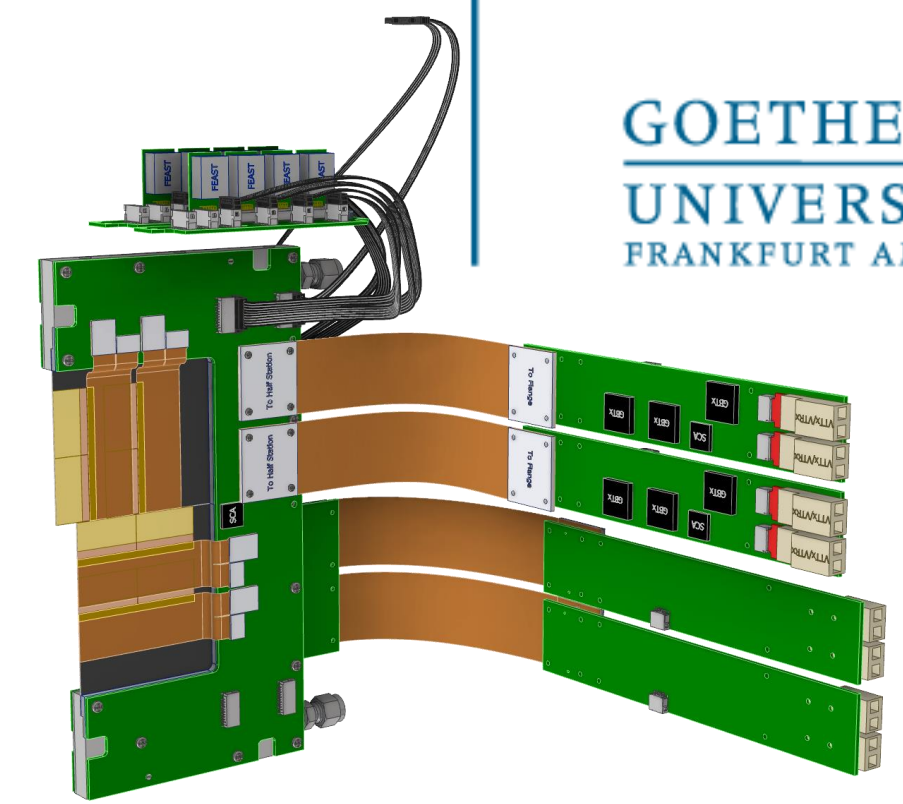
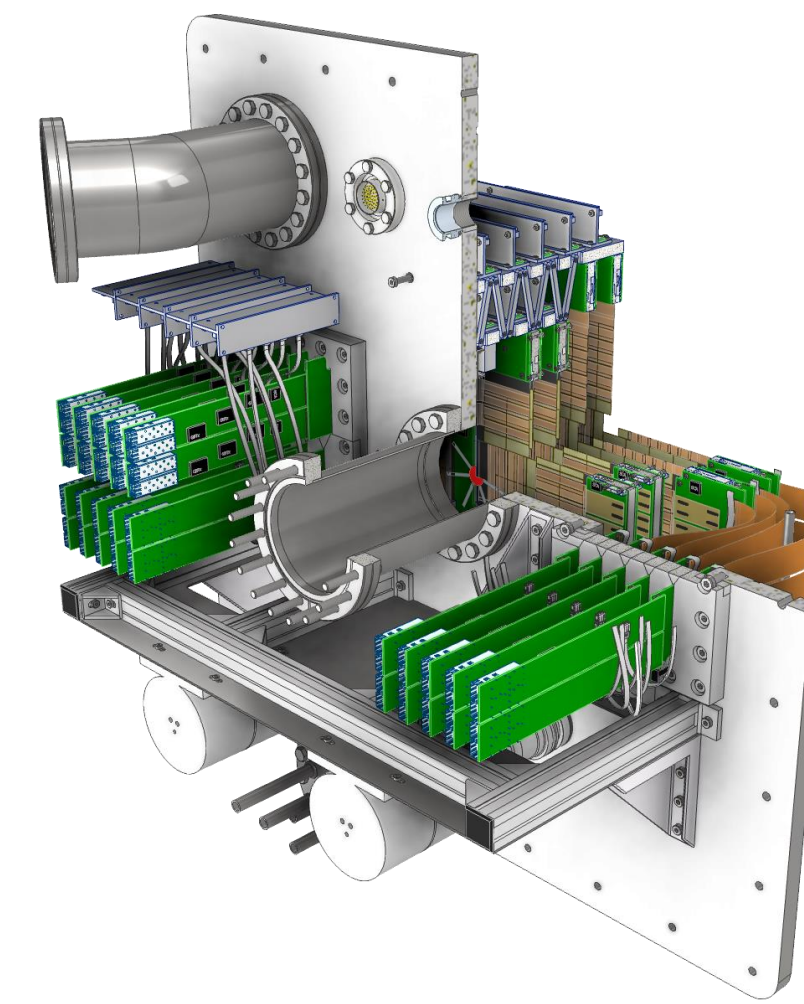




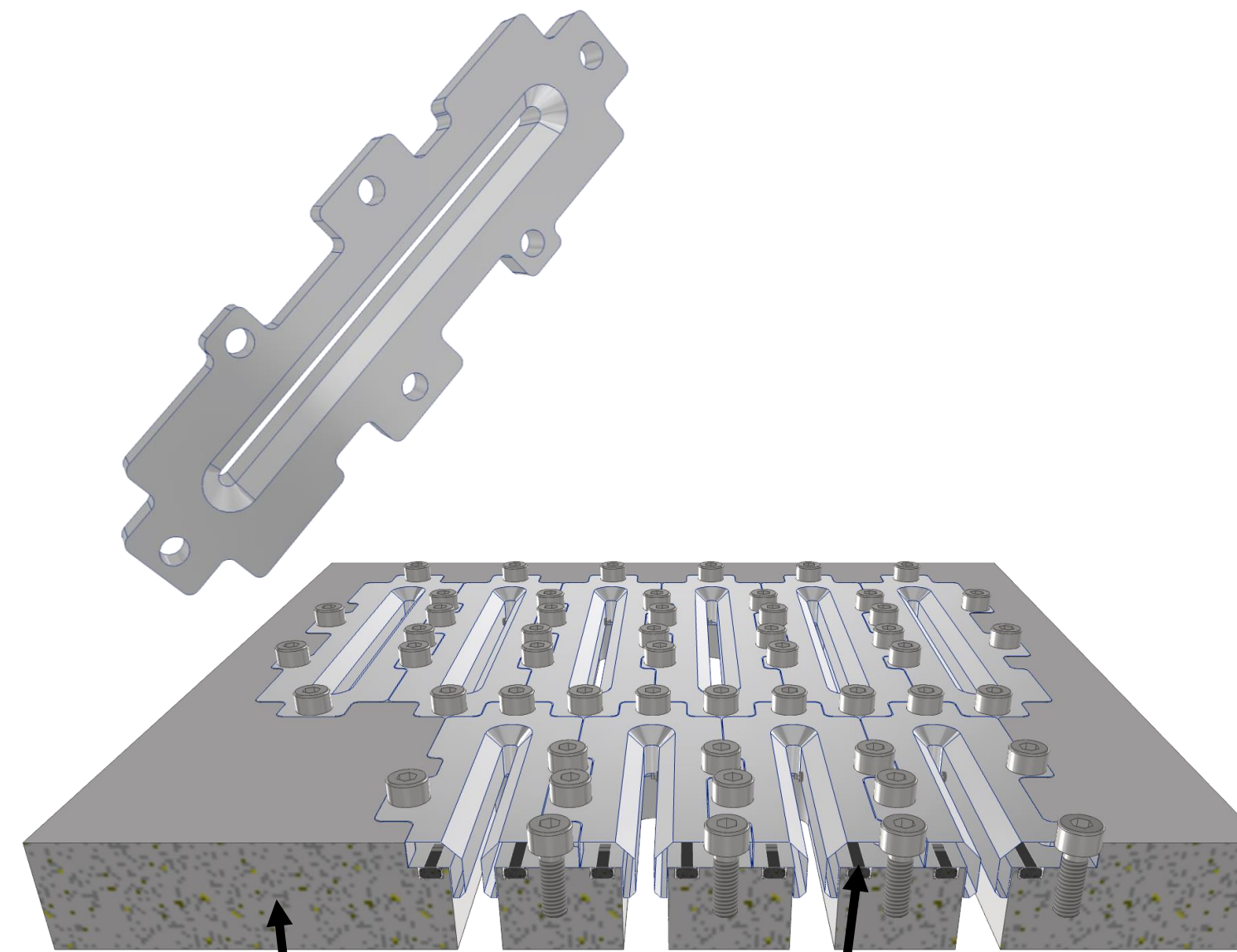
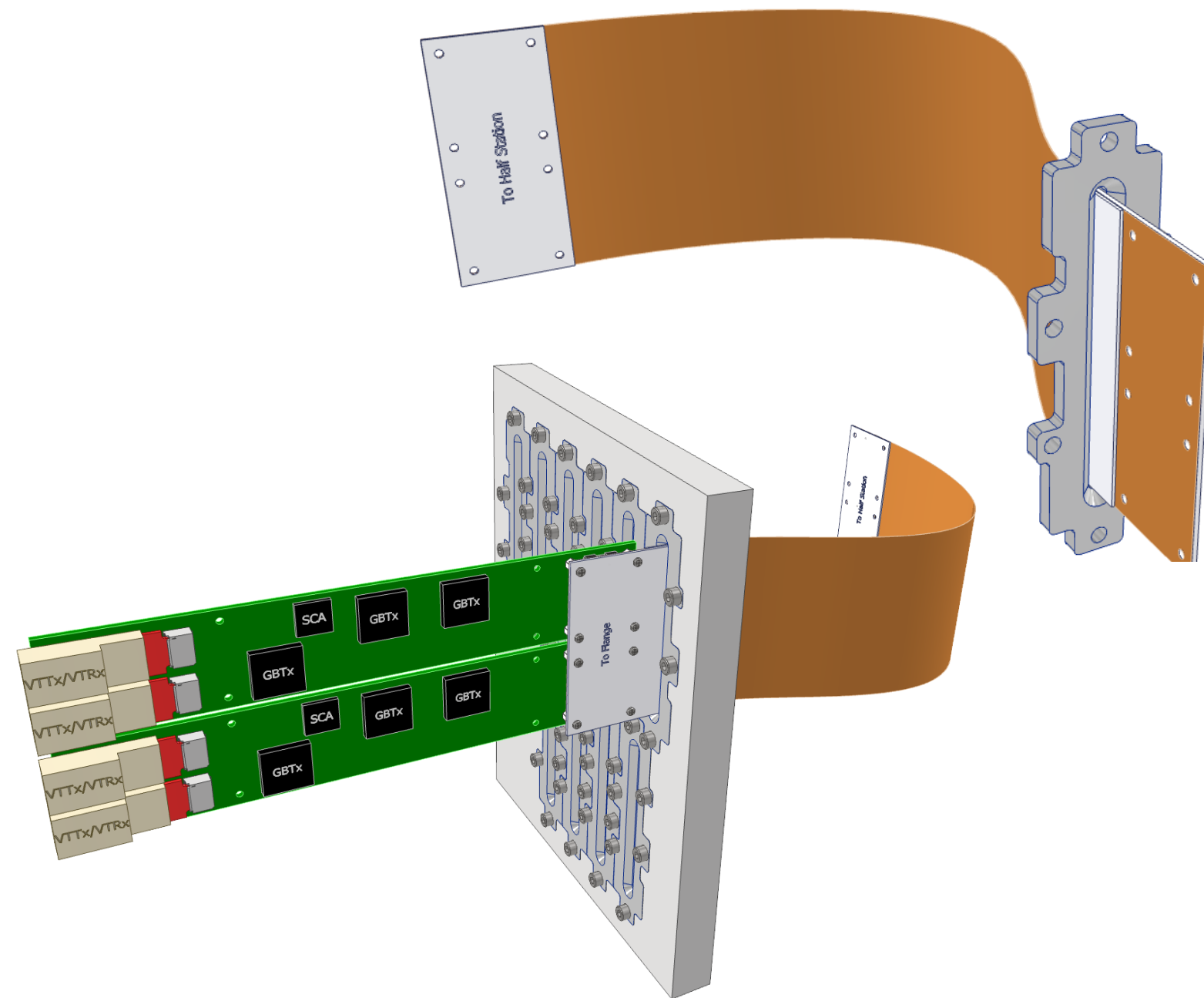
# Data Feedthroughs

High-density feedthrough

- From monolithic (TDR) to fully modular design
- Modules mounted directly onto Front Flange
- Prototype (and QA) flange in production



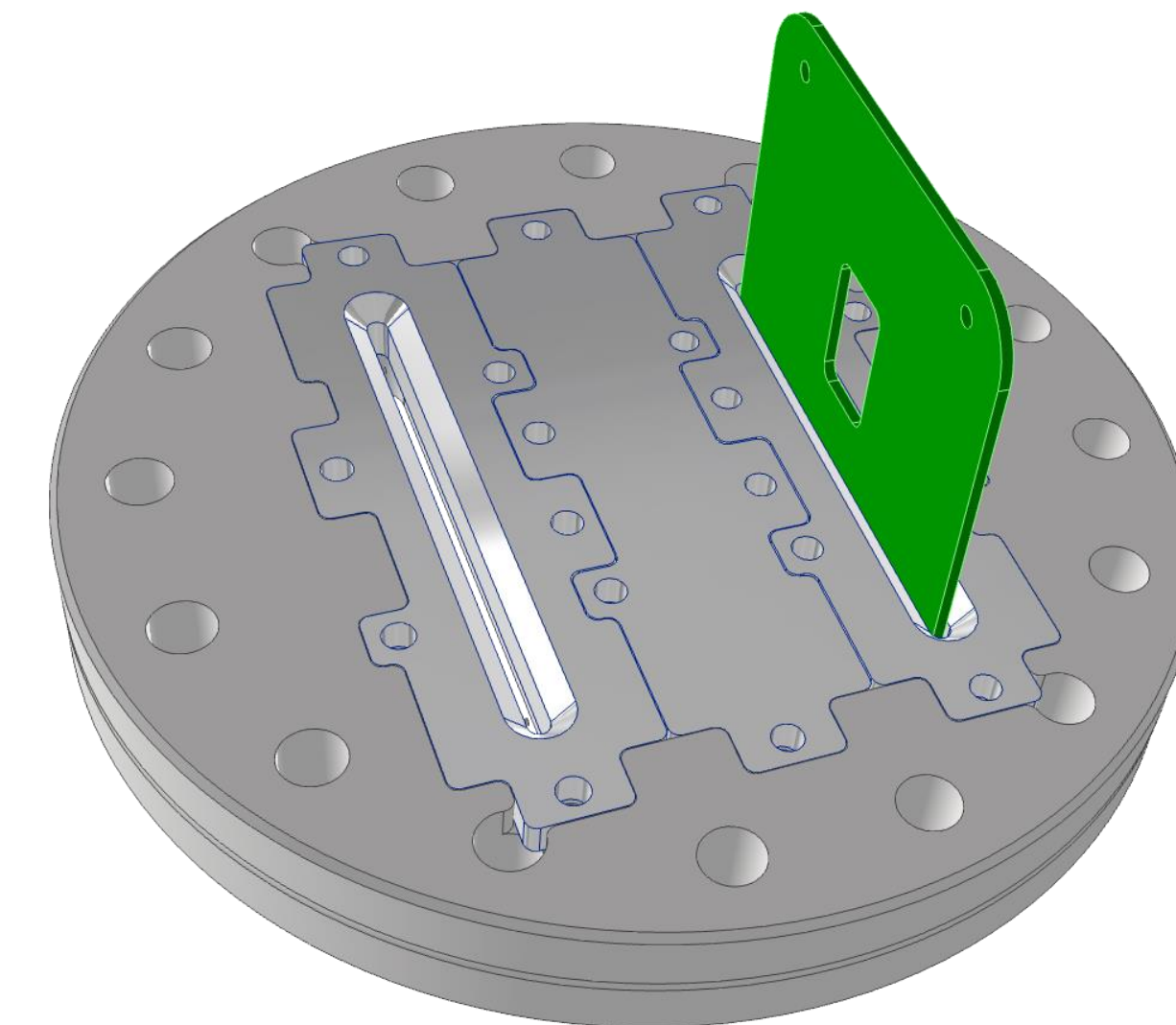
Modular, stiffened FPC-based



In Front Flange

EPDM O-Ring

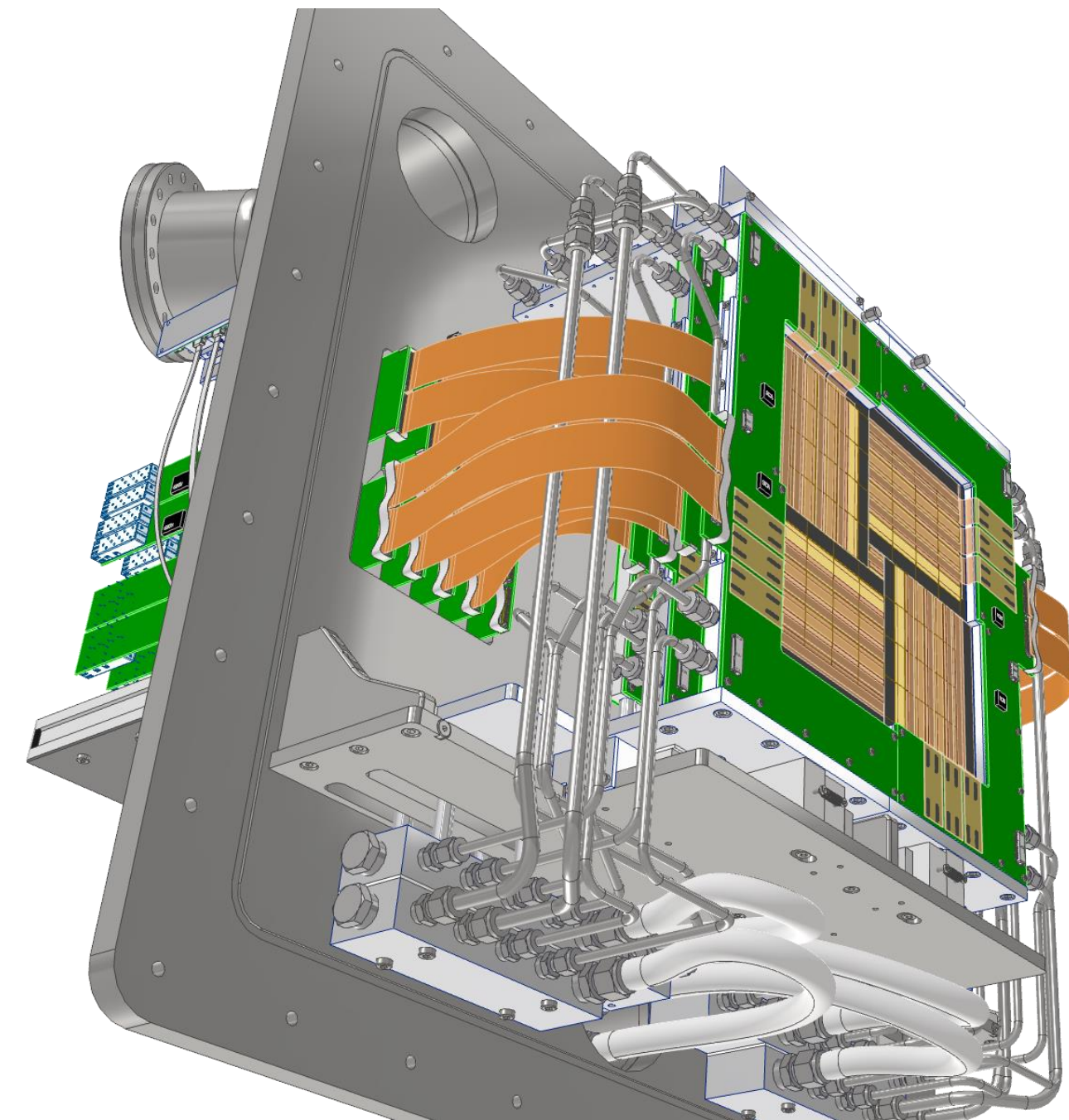
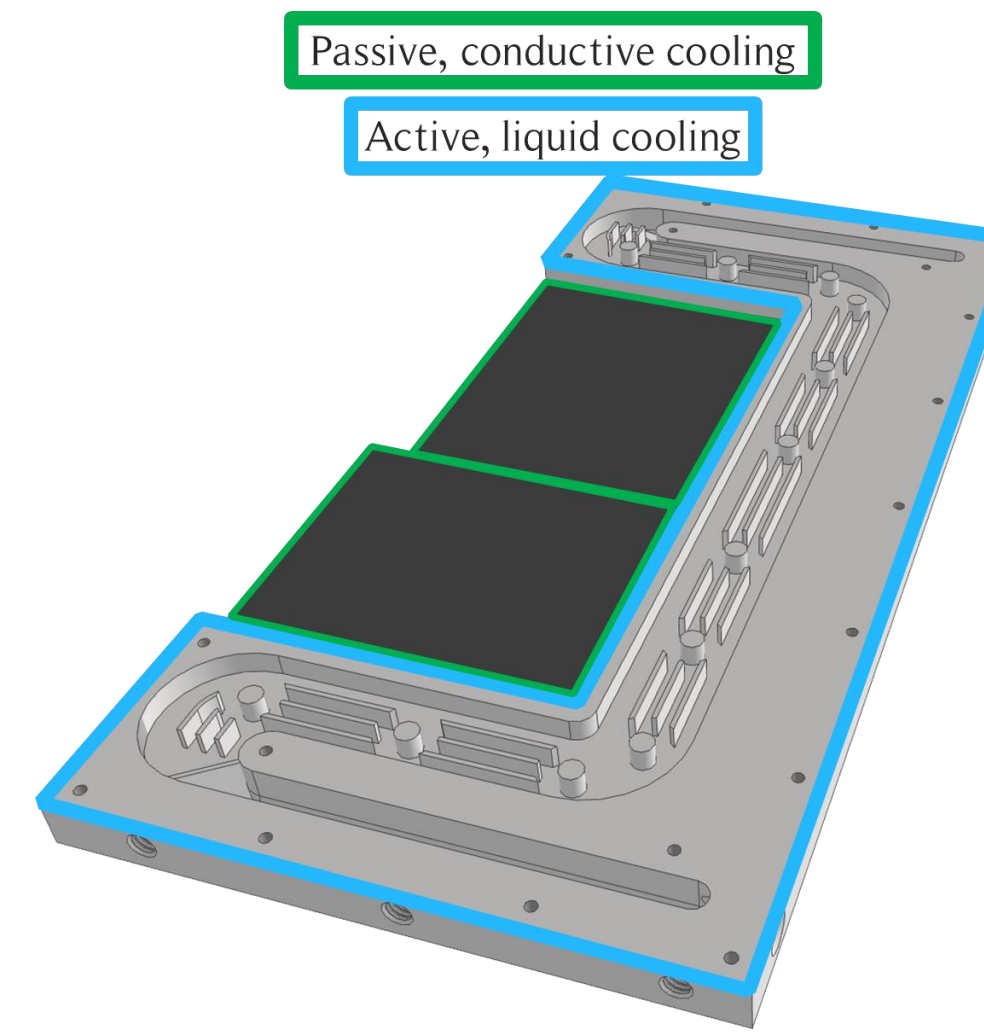
Prototype/QA flange  
for three modules





# Cooling System

Approach validated: Low-mass conductive & mono-phase liquid  
LV (FEASTs): serial with heat sinks  
Heat sink design final, performance validated, pre-series produced  
Prototype vacuum feedthrough validated  
Water-based cooling  
→ Operational parameters with safety margins from CFD  
→  $dV/dt \approx 10$  l/min,  $\Delta p \approx 0.2$  bar,  $\Delta T(\text{In/Out}) \approx 0.4$  K

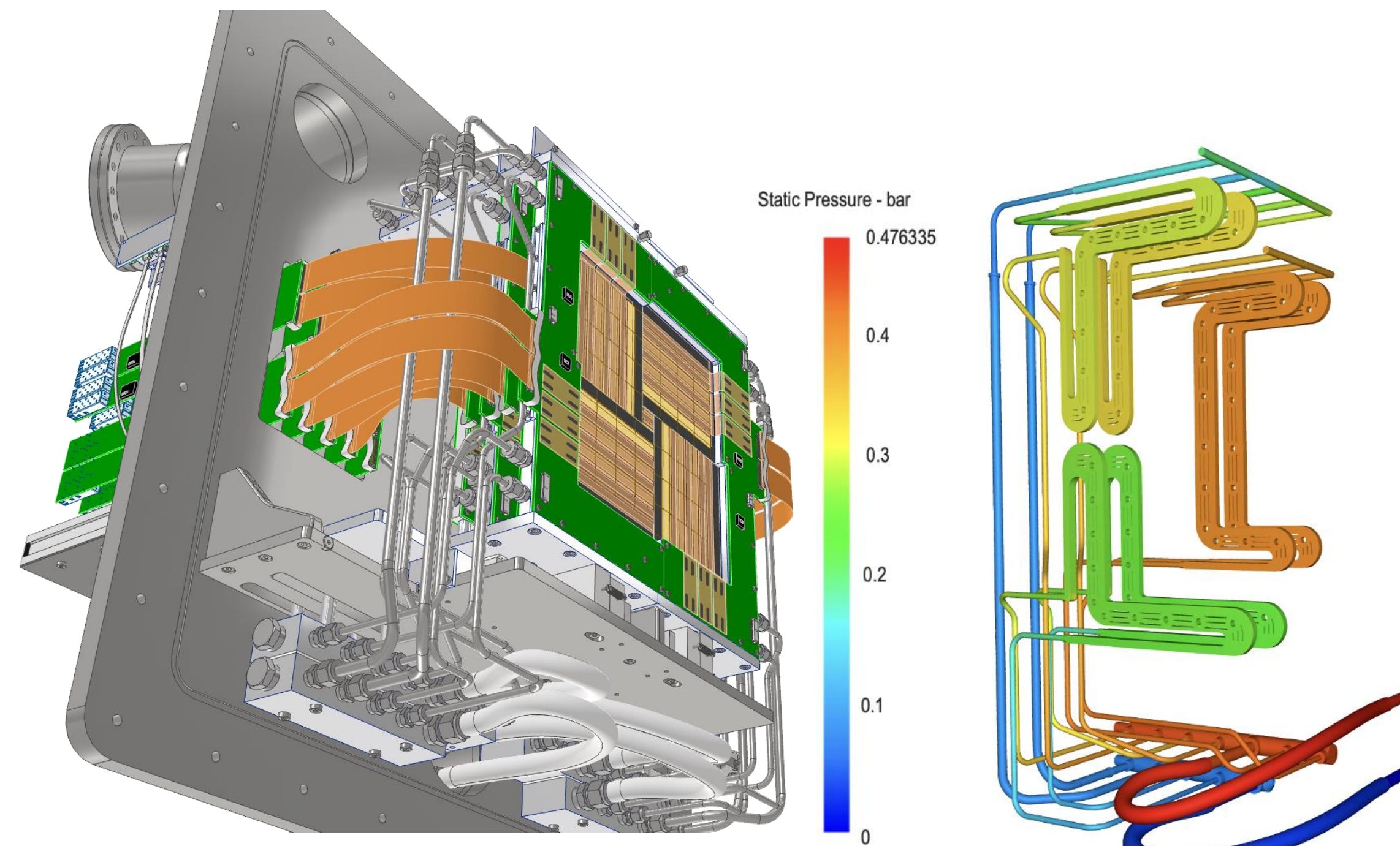
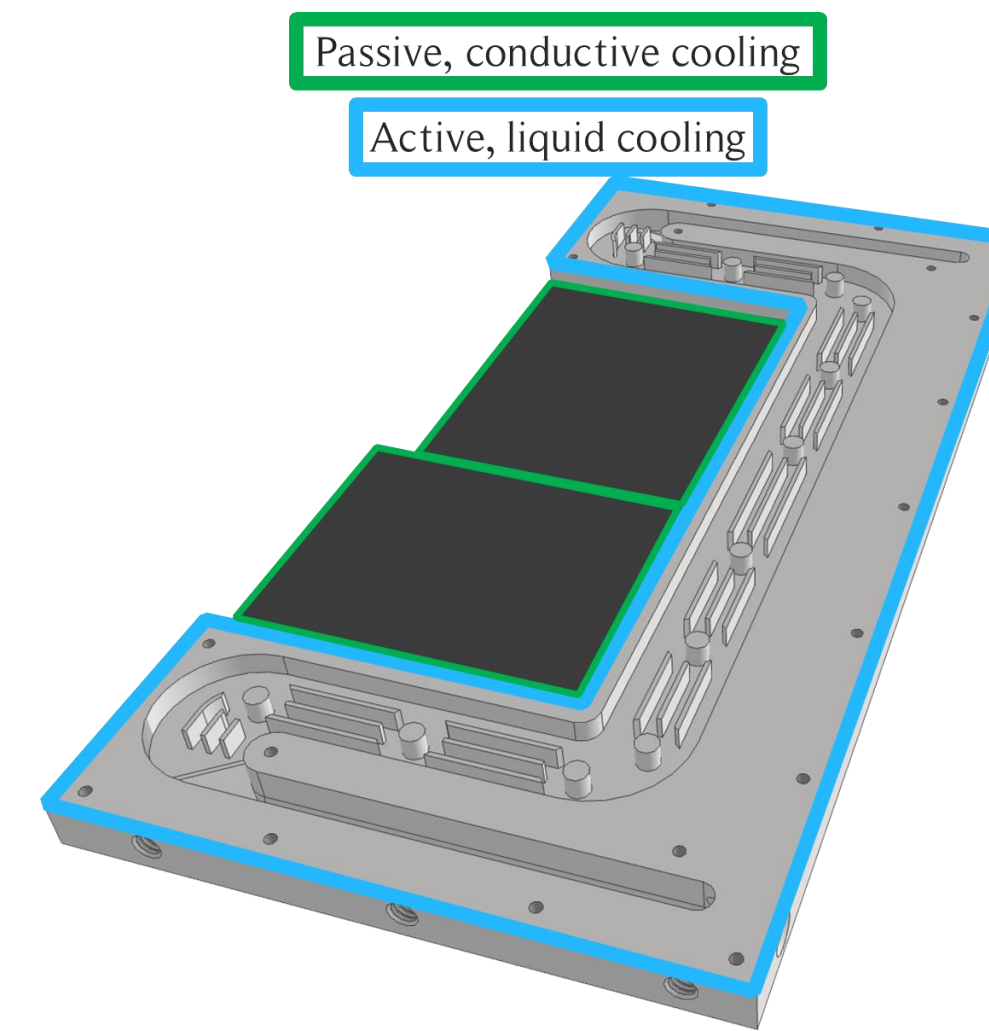


Christopher Braun, FM

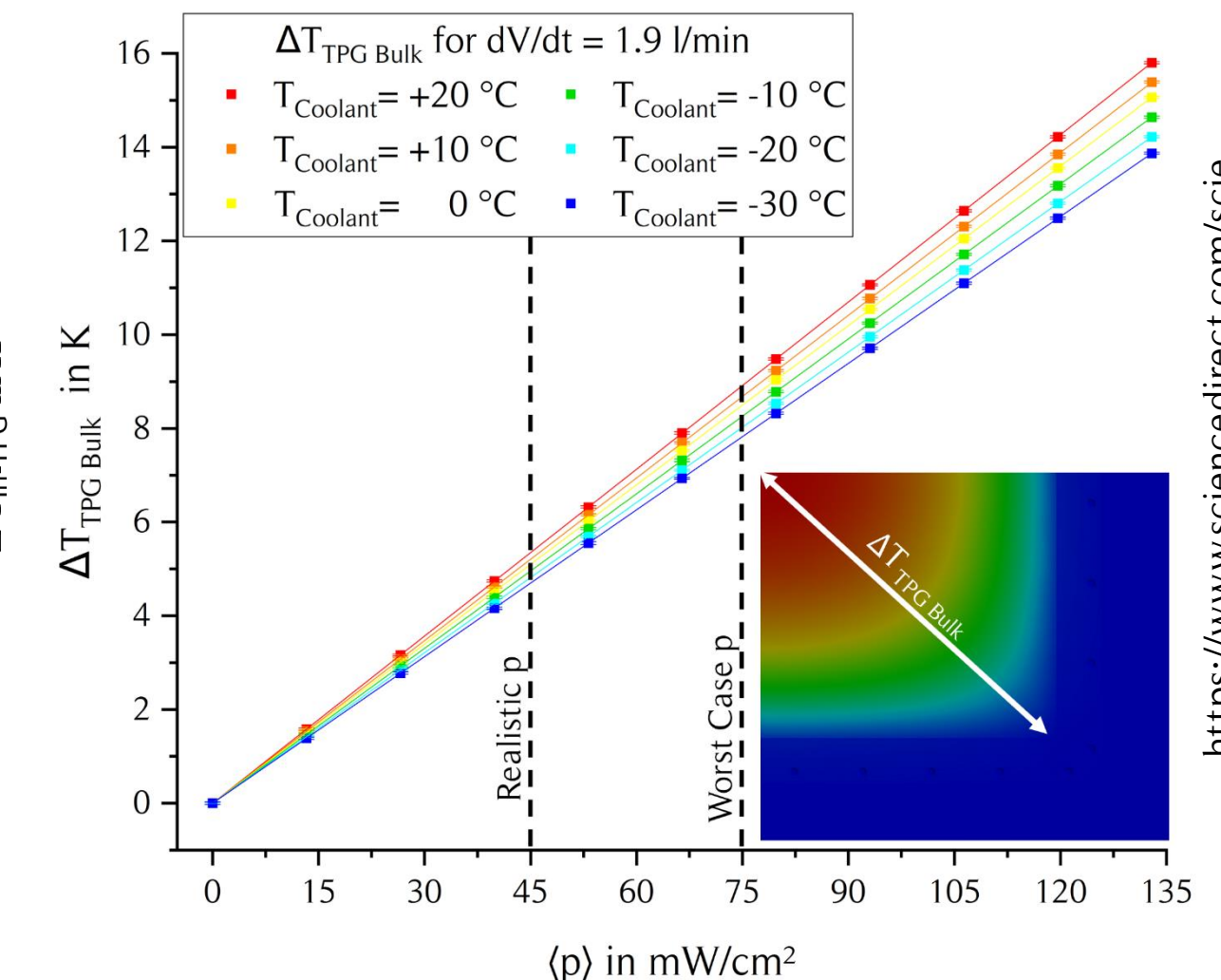
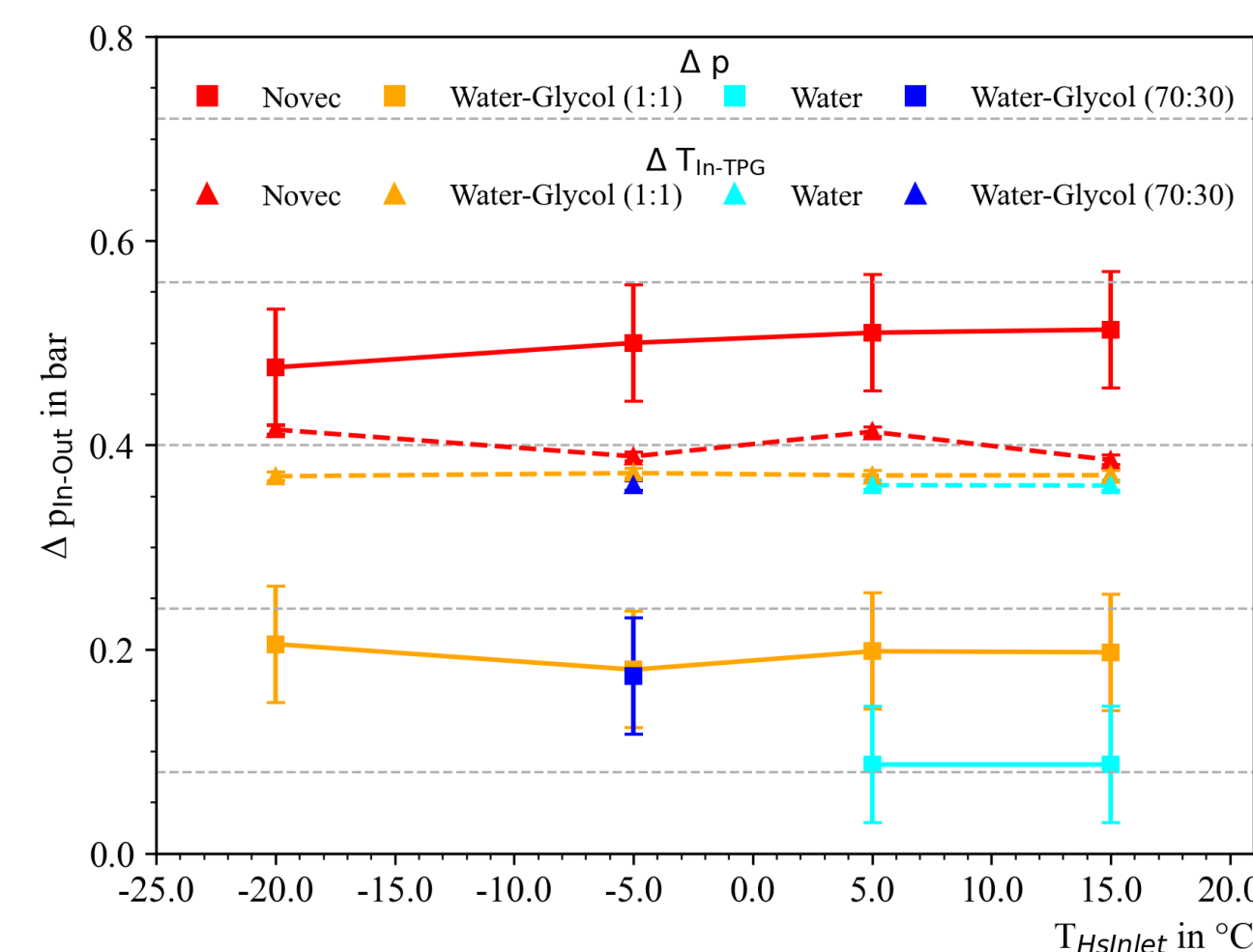


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Thermal performance detector (left, sim.) and quadrant (right, meas.)

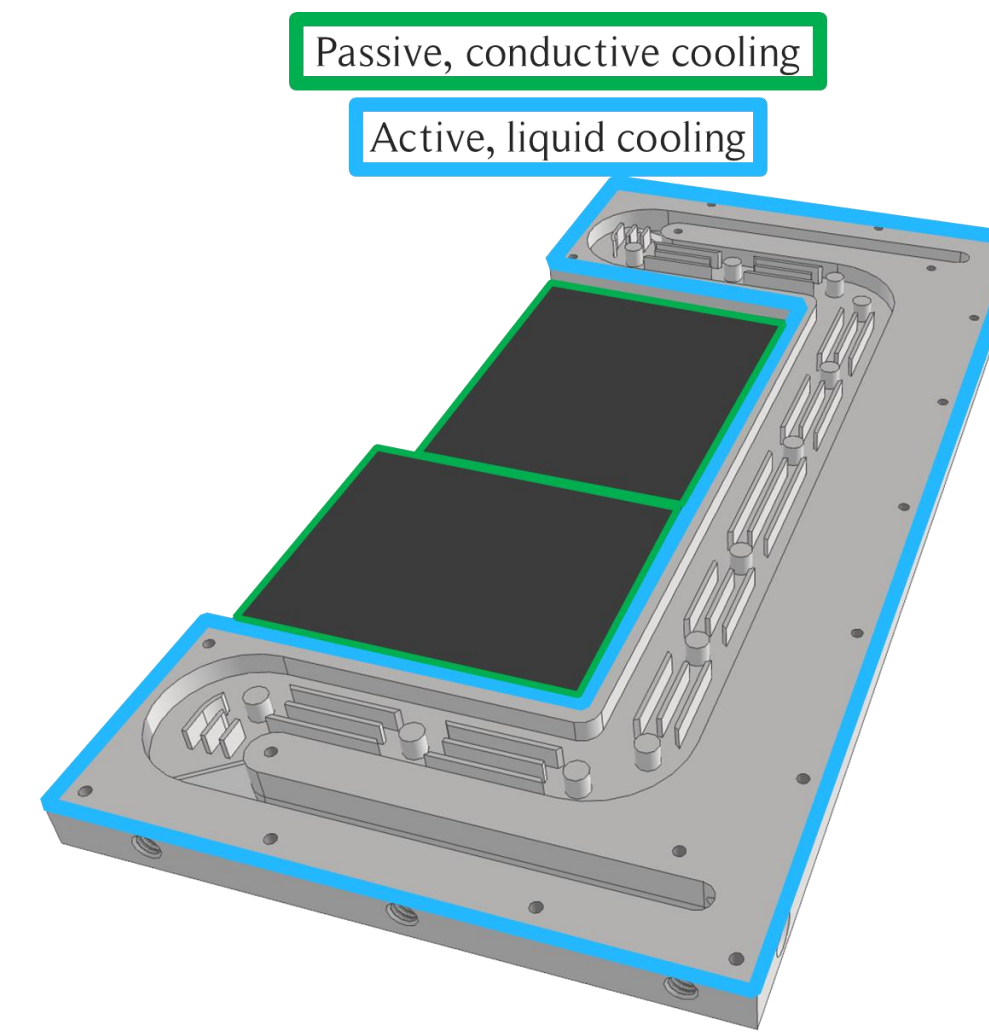


Christopher Braun, FM

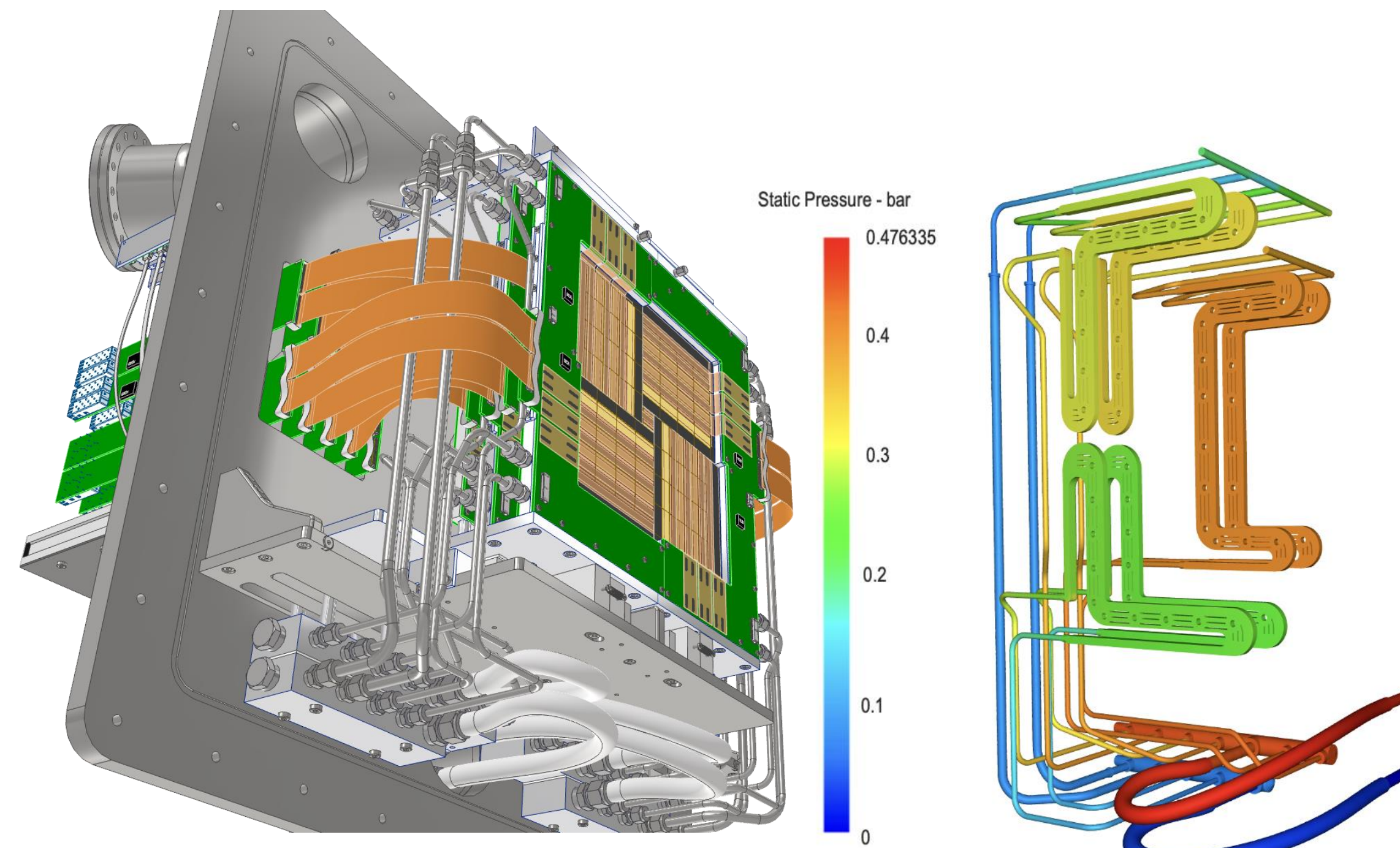


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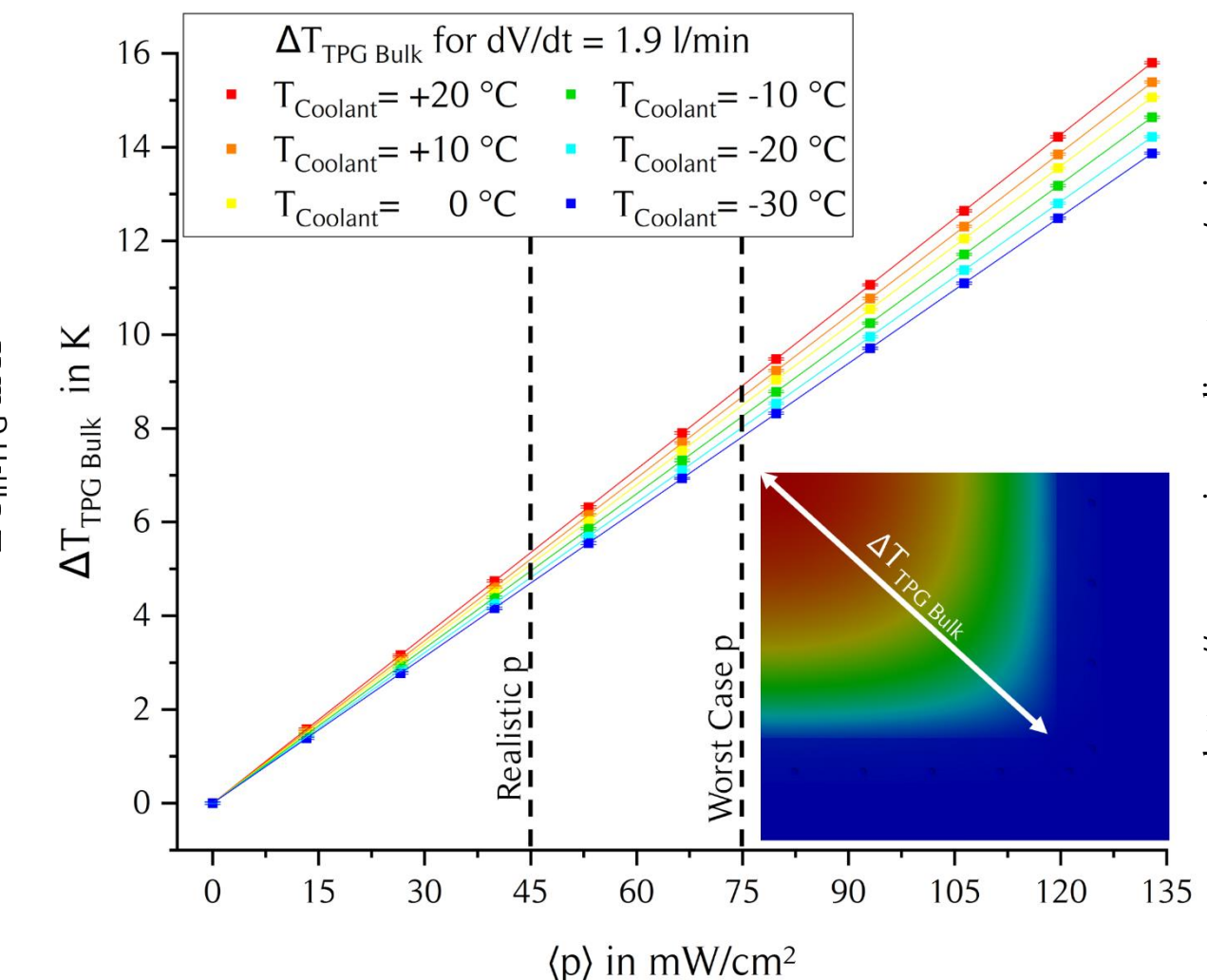
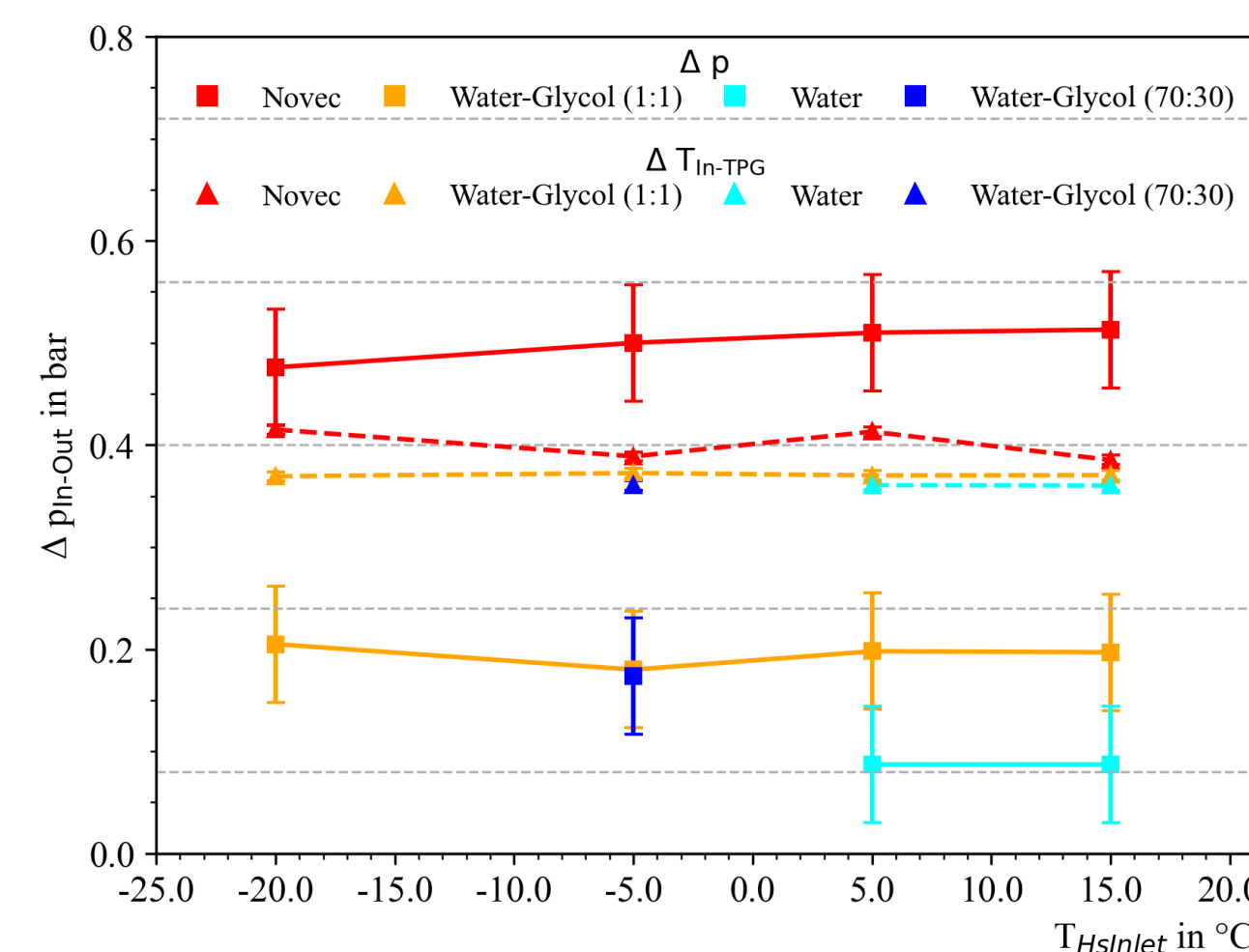
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Thermally insulated coolant feedthrough prototype



Thermal performance detector (left, sim.) and quadrant (right, meas.)



Christopher Braun, FM

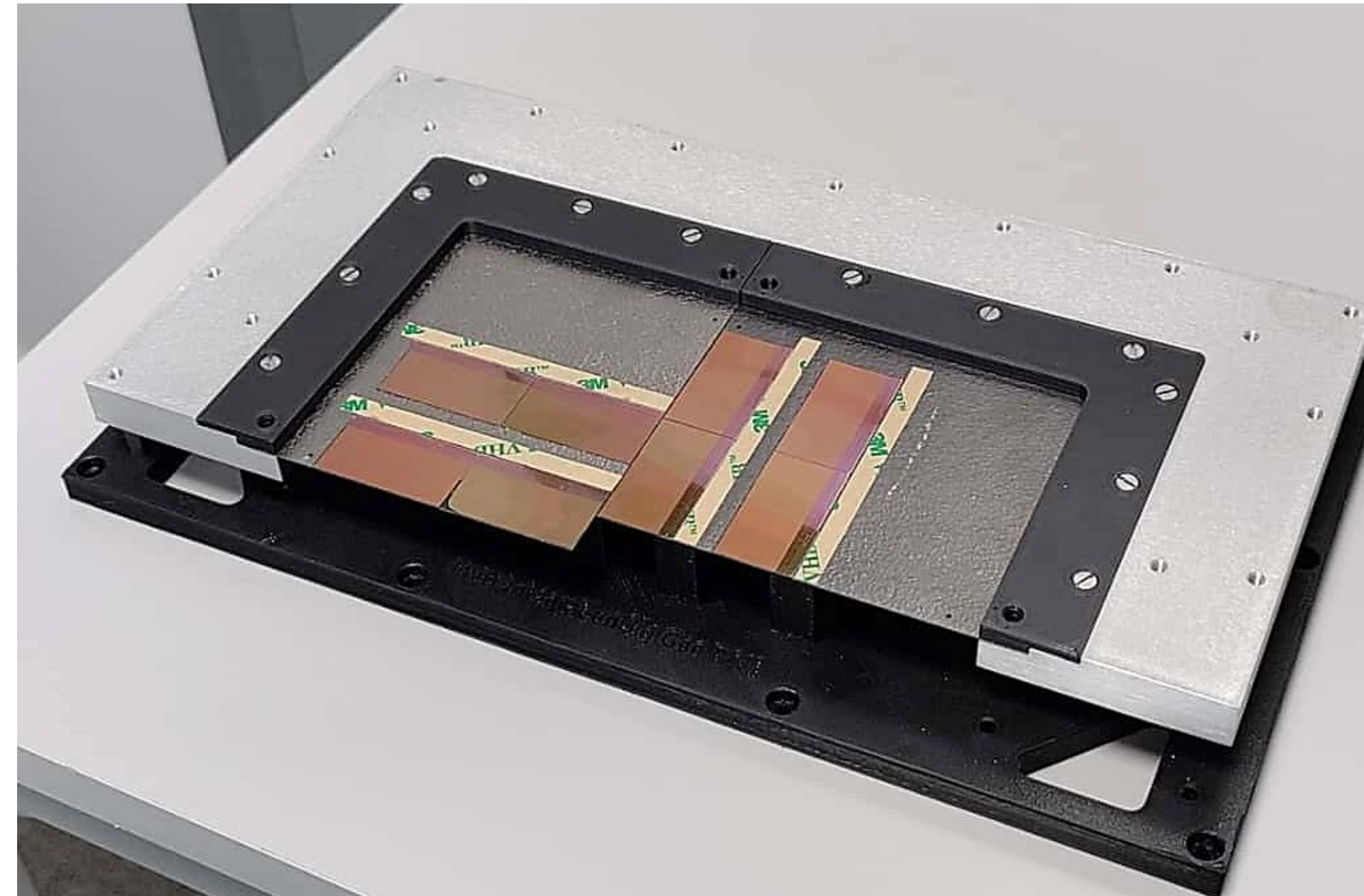


# Carriers

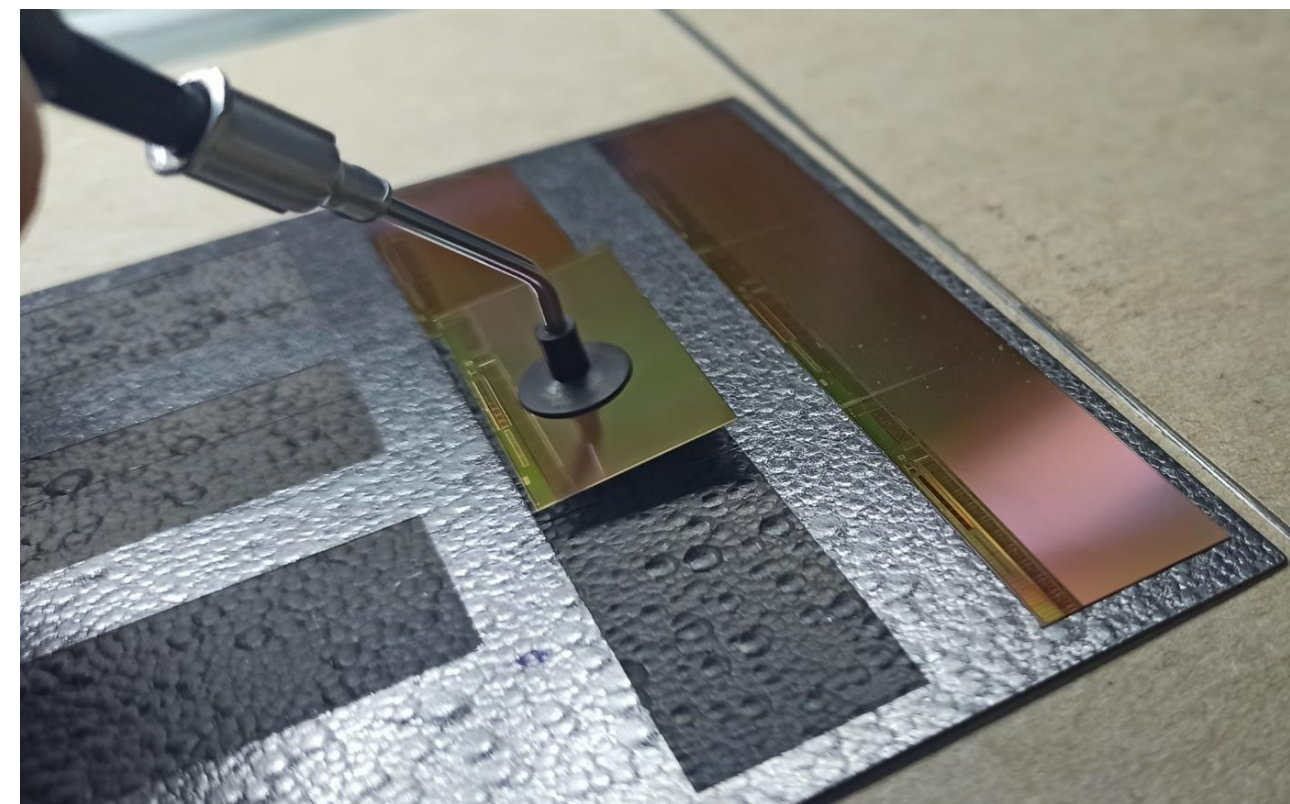
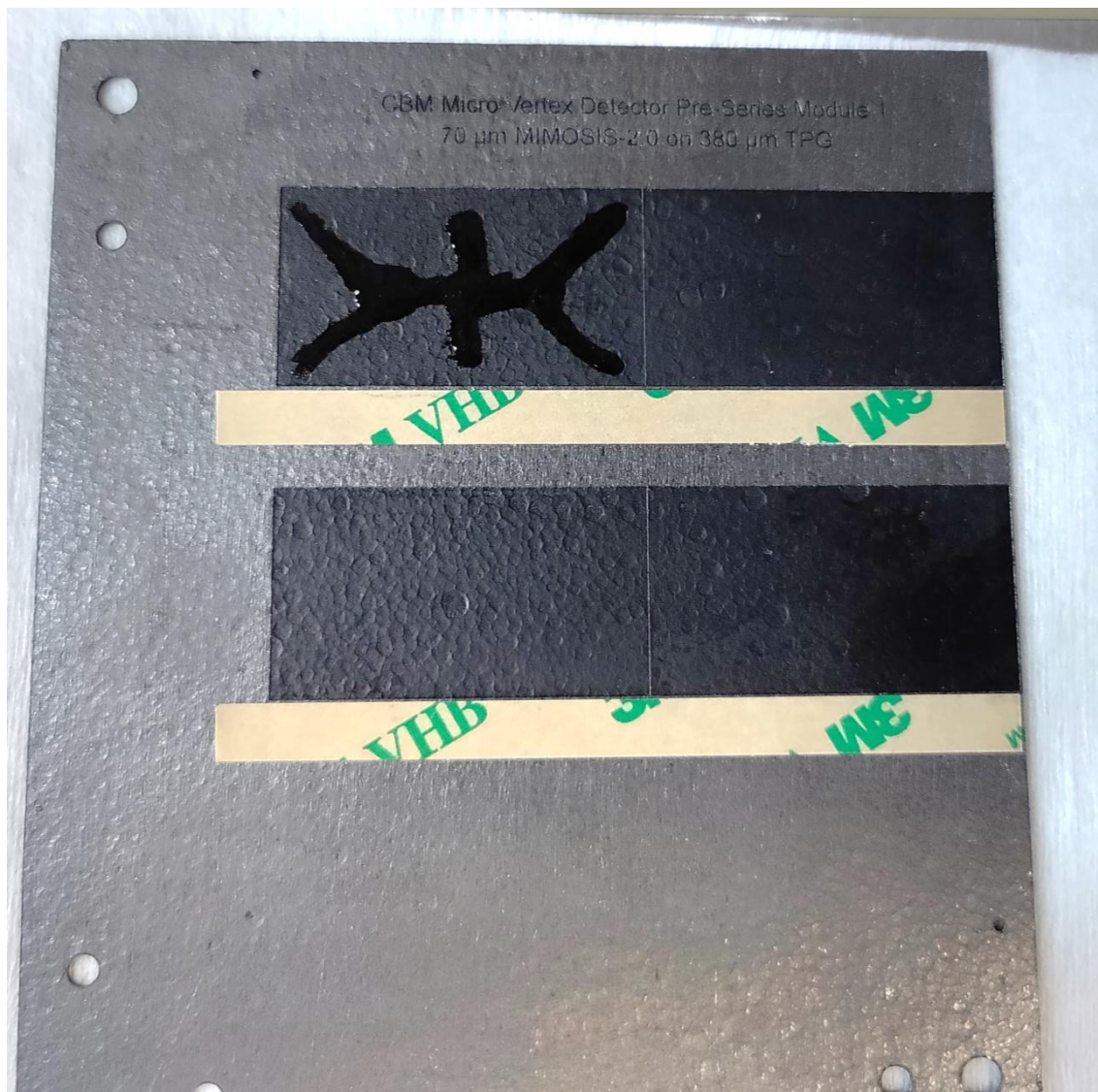
TPG preparation process finalized and validated  
→ Polishing, 3D laser-structuring, coating, plasma activation

Low-material, vacuum-compatible gluing

Alternative vendor geo “c” identified (MinTeq)  
→ Validation ongoing



**MIMOSIS-2 on TPG, half-station geo “b”**





# Jigs

First iteration for gluing (sensors/FPC)

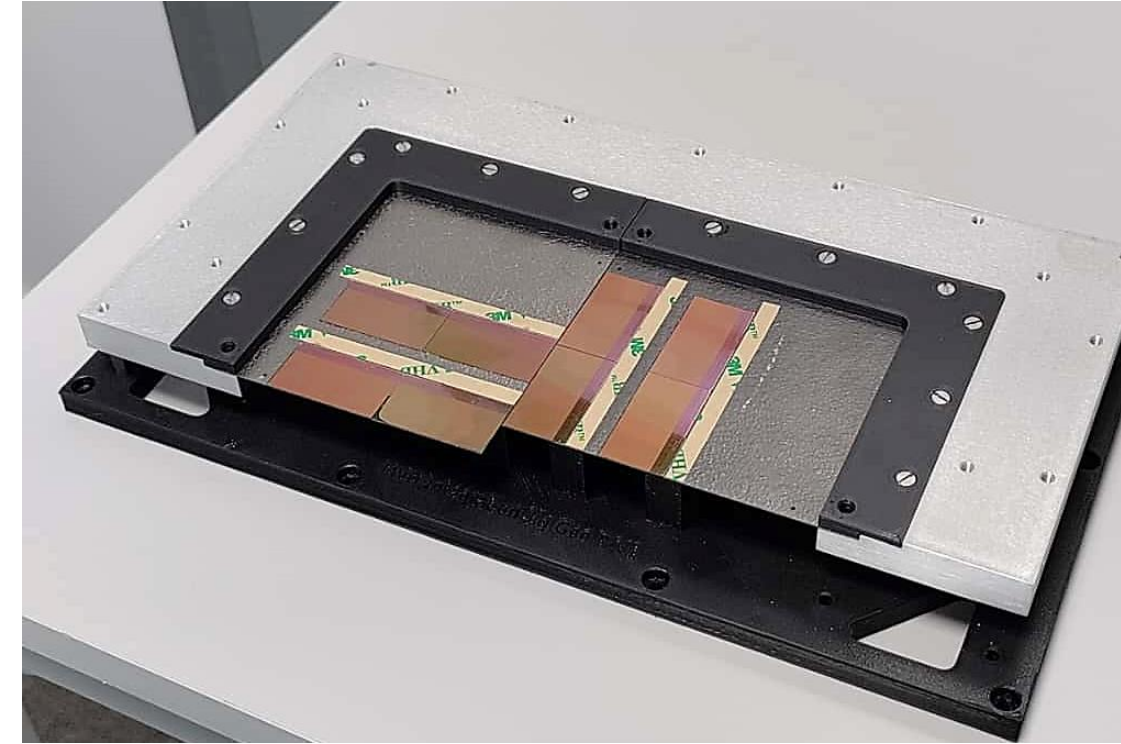
FPC placement being optimized

→ 2 pin jig + manual placement

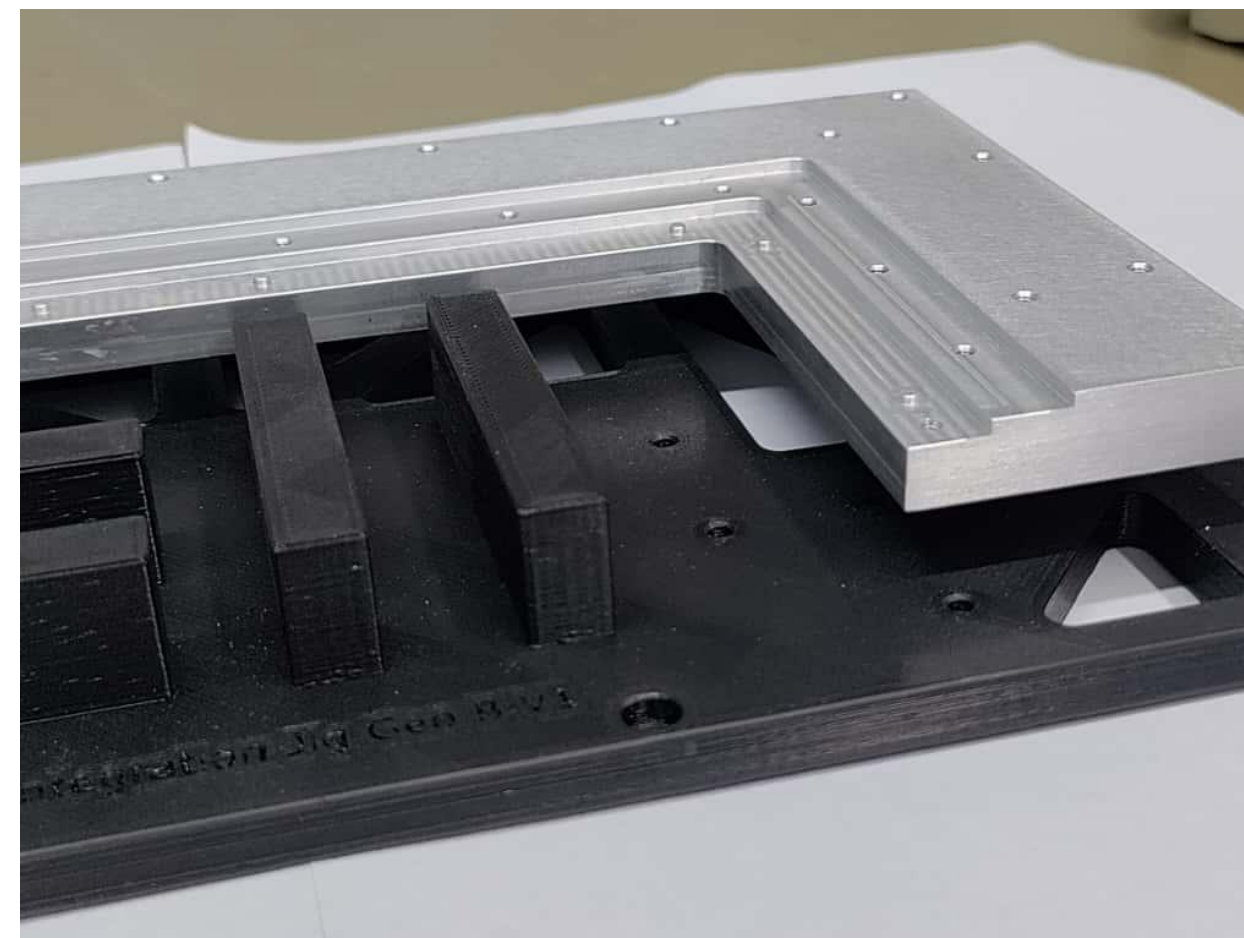
→ With micro-stage + vacuum adapter

Bonding jig similar, w/ vacuum for support

→ Double-sided integration!



MVD jig geo “b” 1<sup>st</sup>  
iteration (ESD 3D-print)





# Jigs

First iteration for gluing (sensors/FPC)

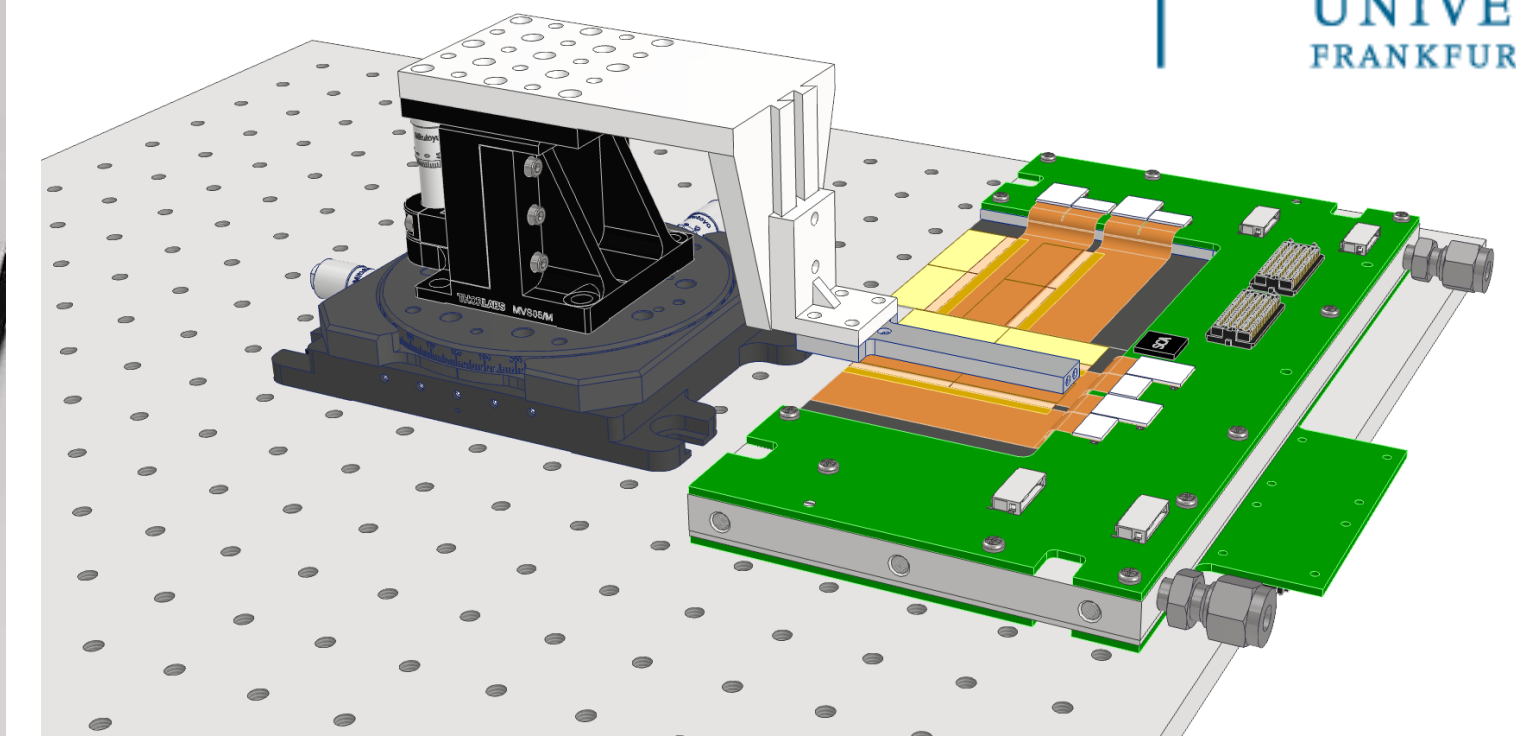
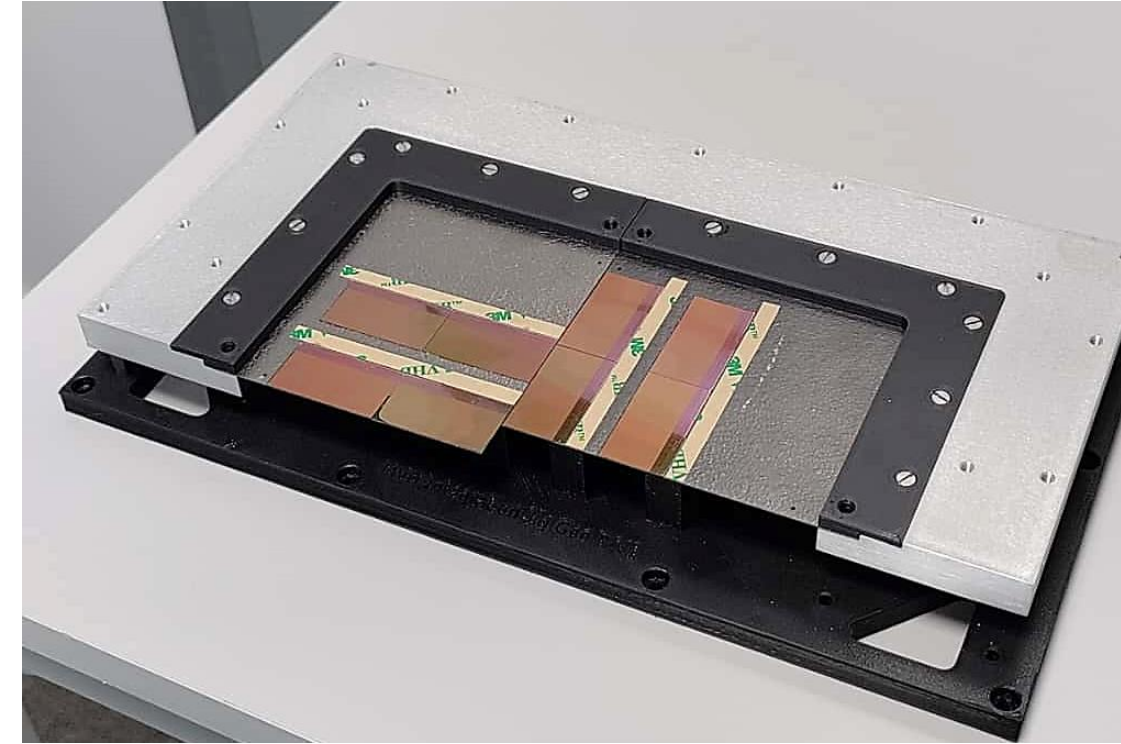
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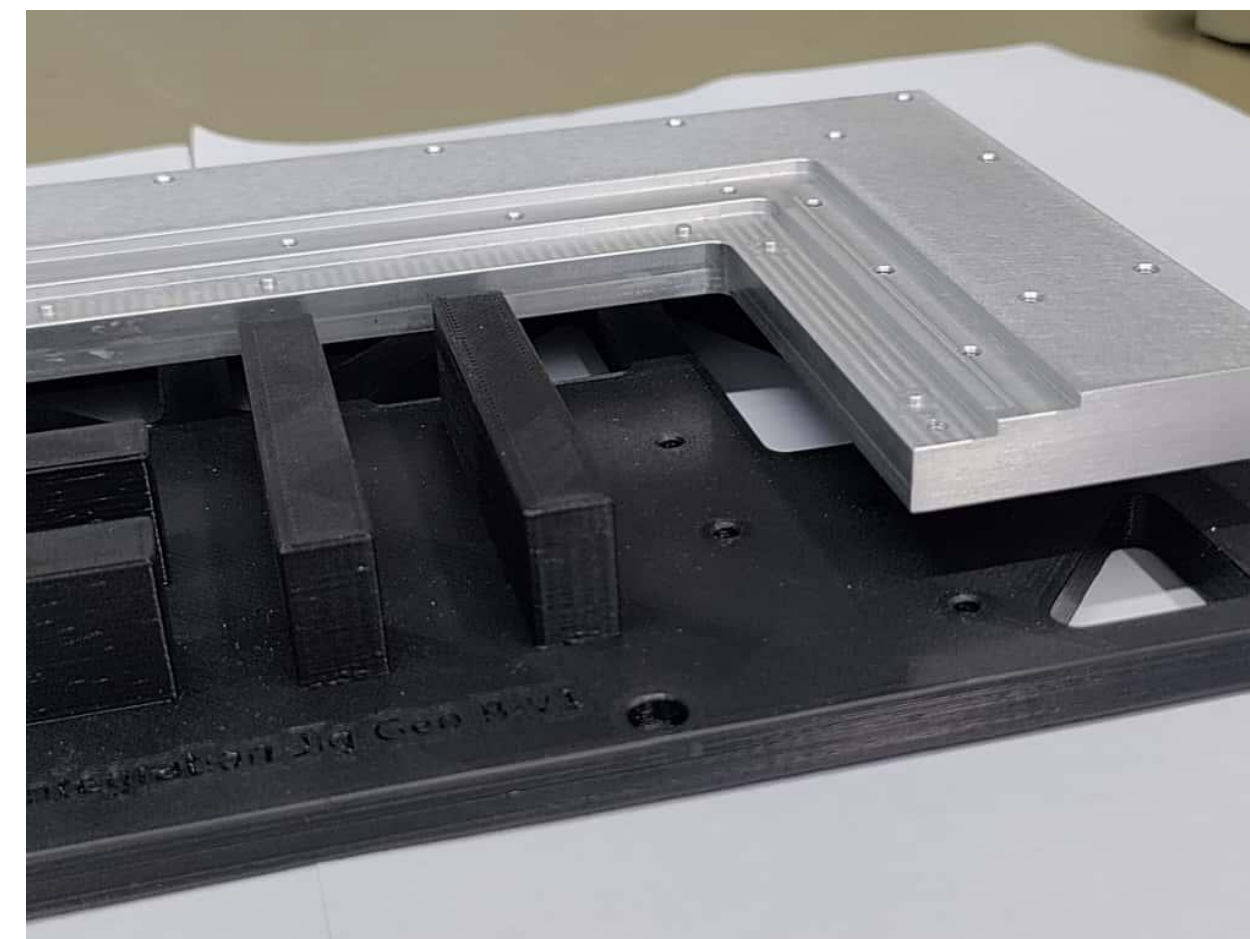
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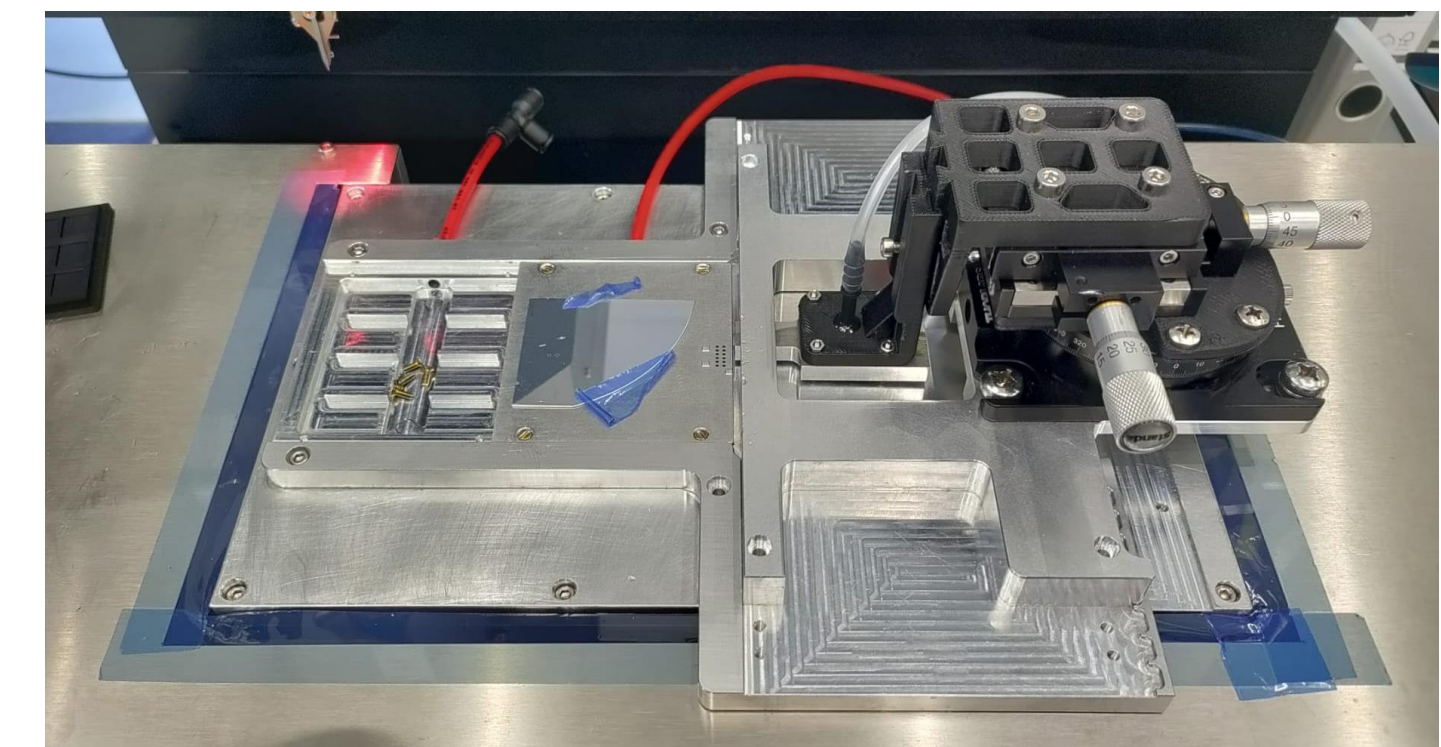
→ Double-sided integration!



MVD jig geo “b” 1<sup>st</sup>  
iteration (ESD 3D-print)



Inspiration: STS  
microcable alignment jig





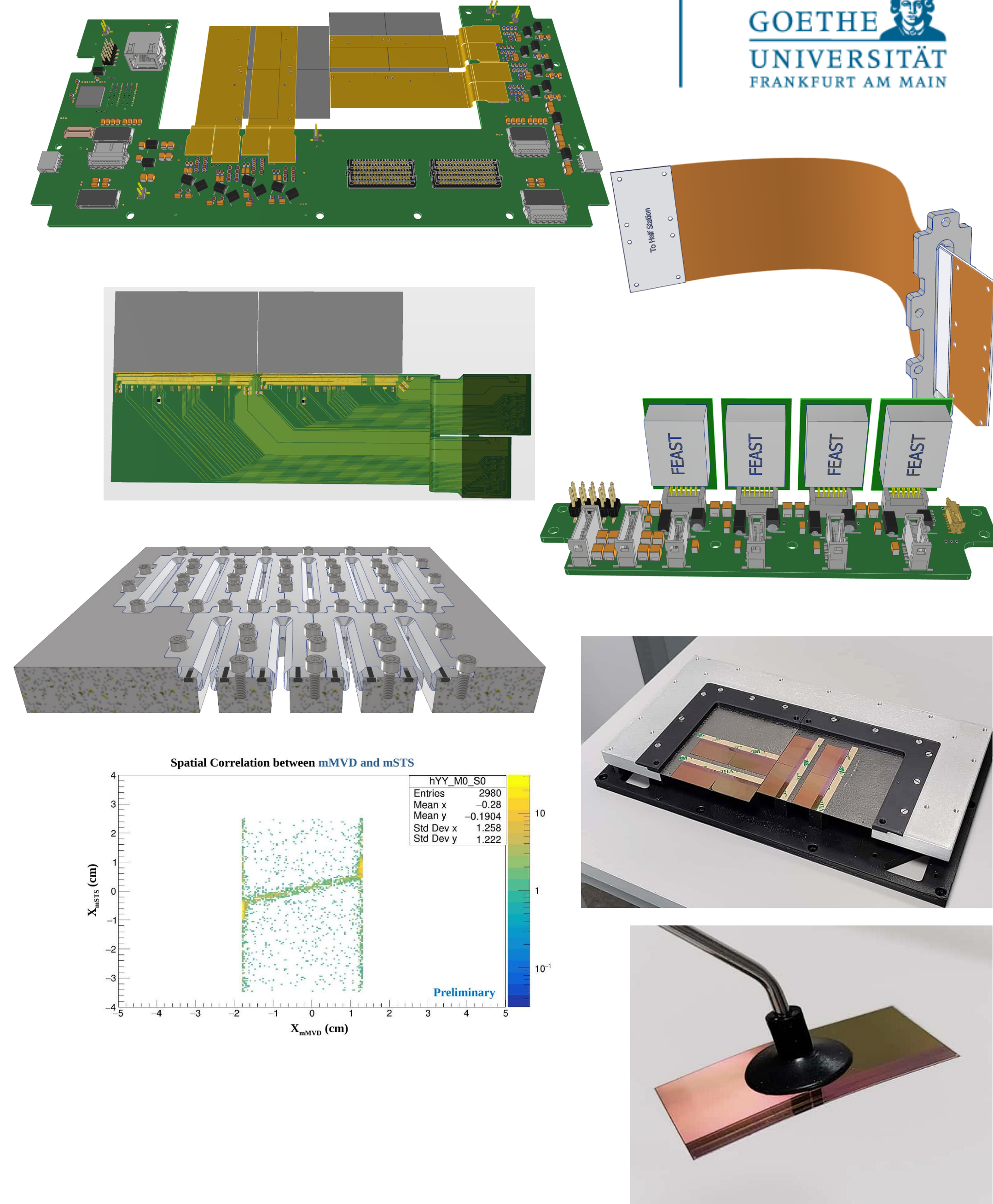
# ... on the Road to Production?

MIMOSIS-2.1 → MIMOSIS-3

Pre-series electronics submission in 11/25

Integration & jigs being optimized

- Many of the key components are done
- Pre-series detector modules with MIMOSIS-2.1 on their way
- MVD Core EDR upcoming
- Preparations for M3 ongoing





# ... on the Road to Production?

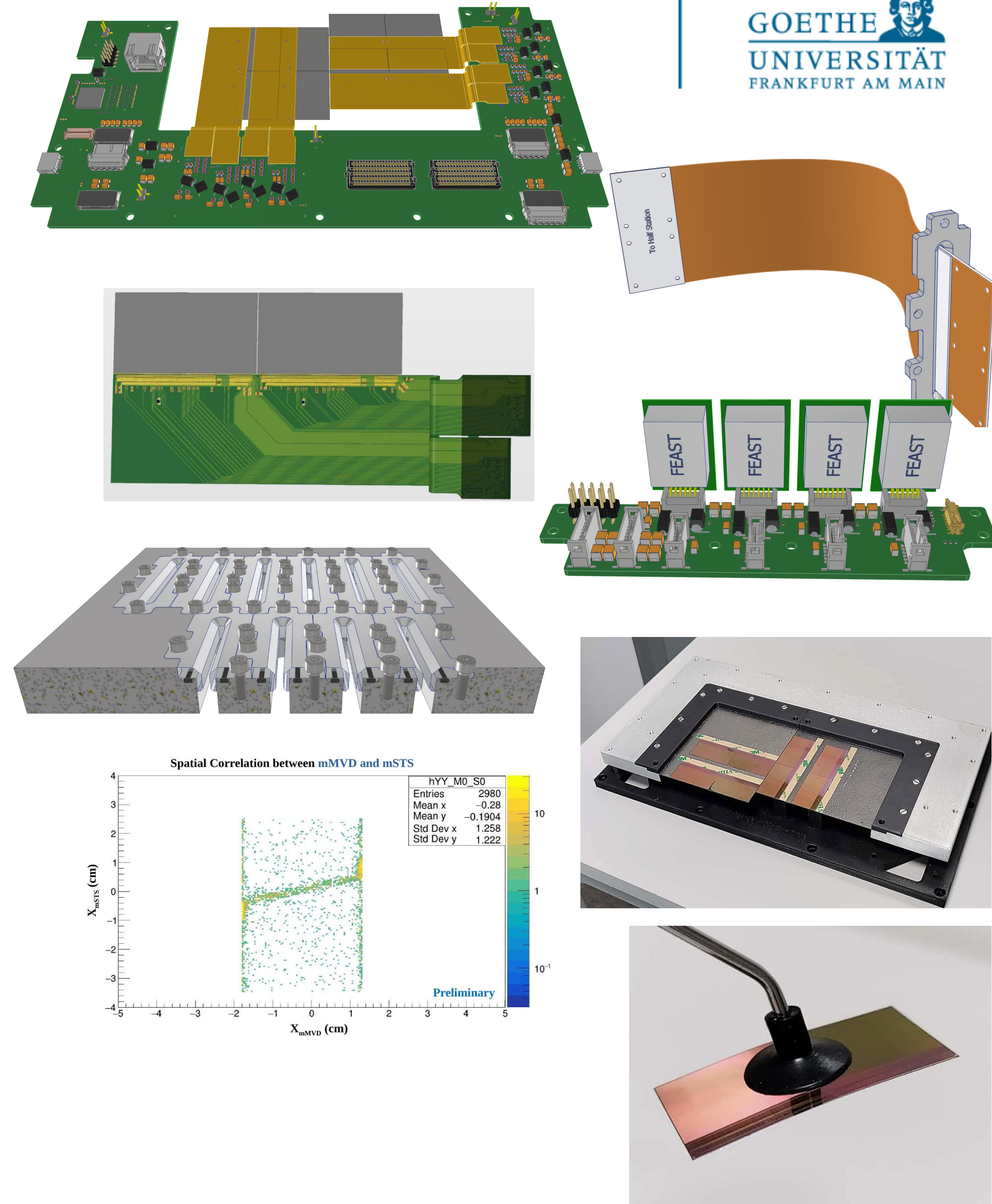
MIMOSIS-2.1 → MIMOSIS-3

Pre-series electronics submission in 11/25

Integration & jigs being optimized

- Many of the key components are done
- Pre-series detector modules with MIMOSIS-2.1 on their way
- MVD Core EDR upcoming
- Preparations for M3 ongoing

## ... ready for CBM 2028!



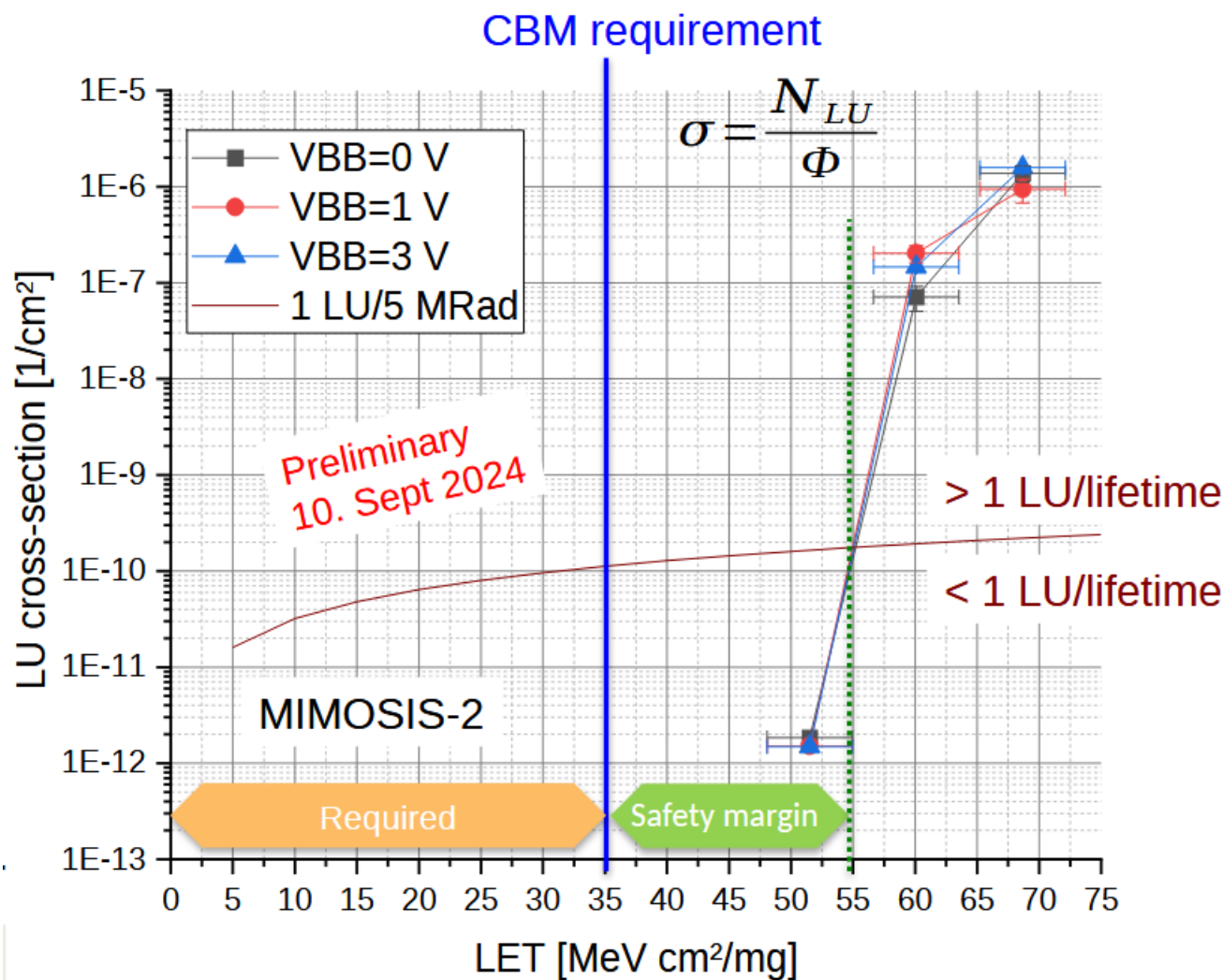


# Backup

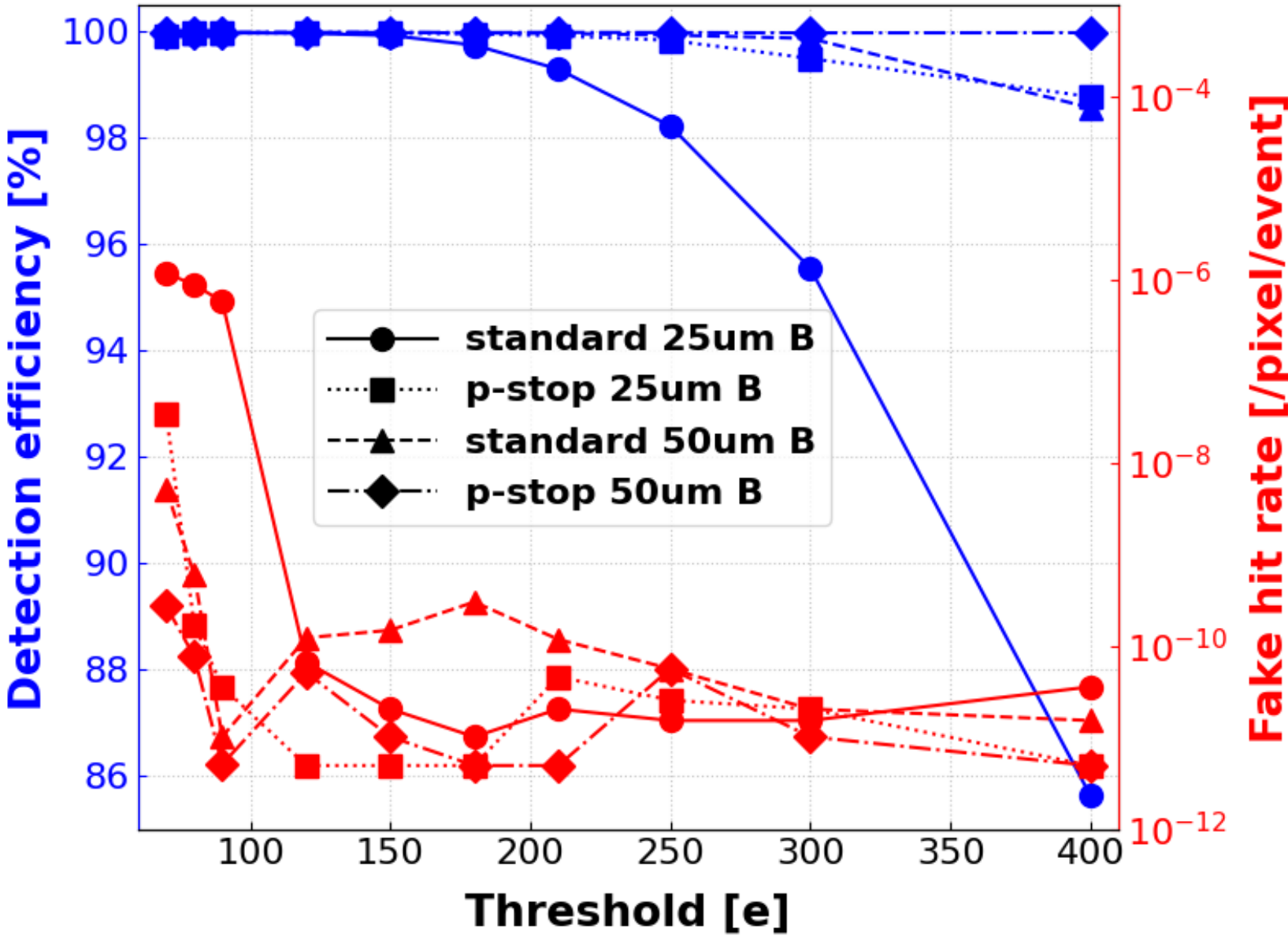


# Sensor Performance

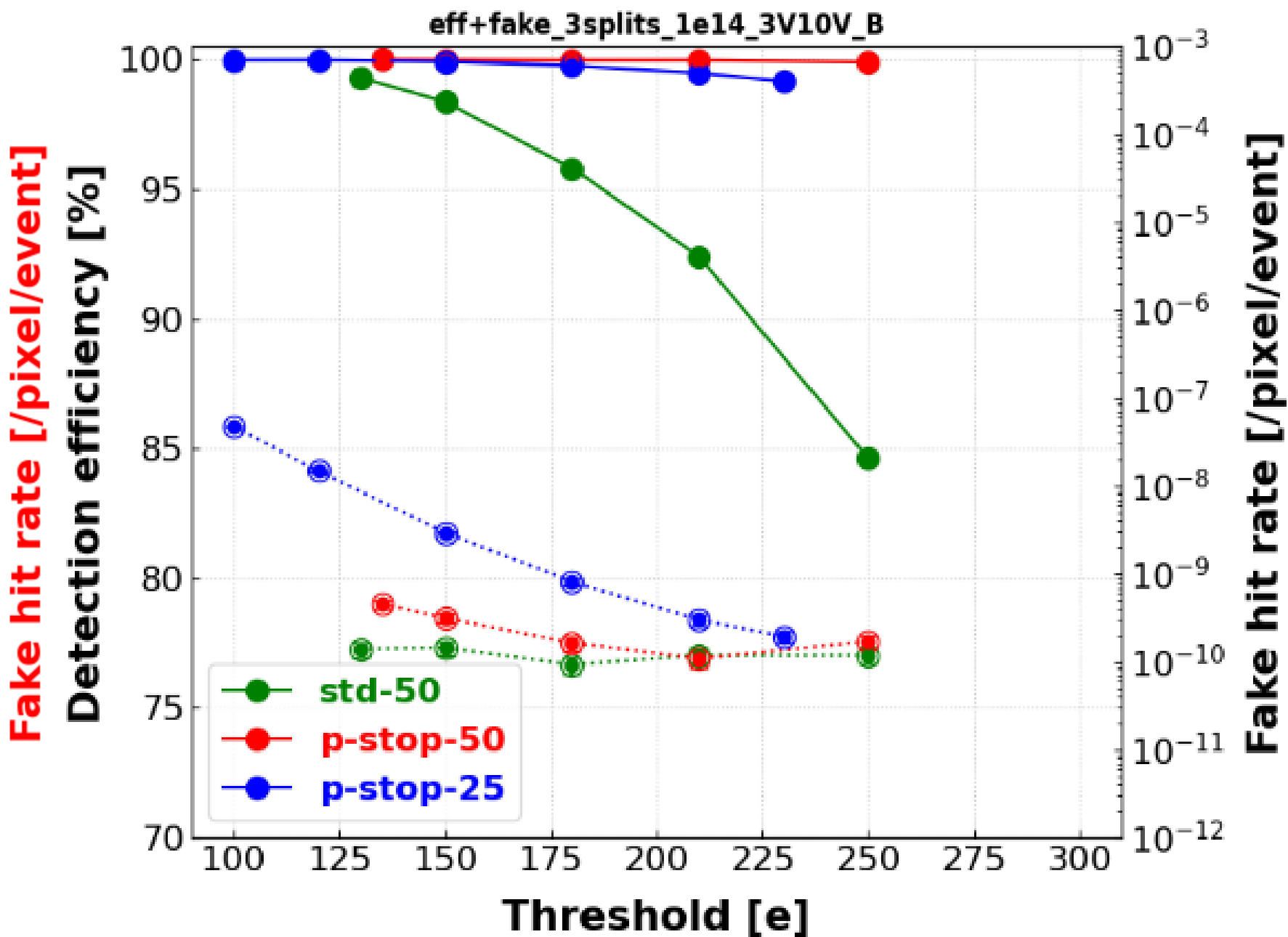
50  $\mu\text{m}$  epi allows for increased operation range  
→ Parameter stability



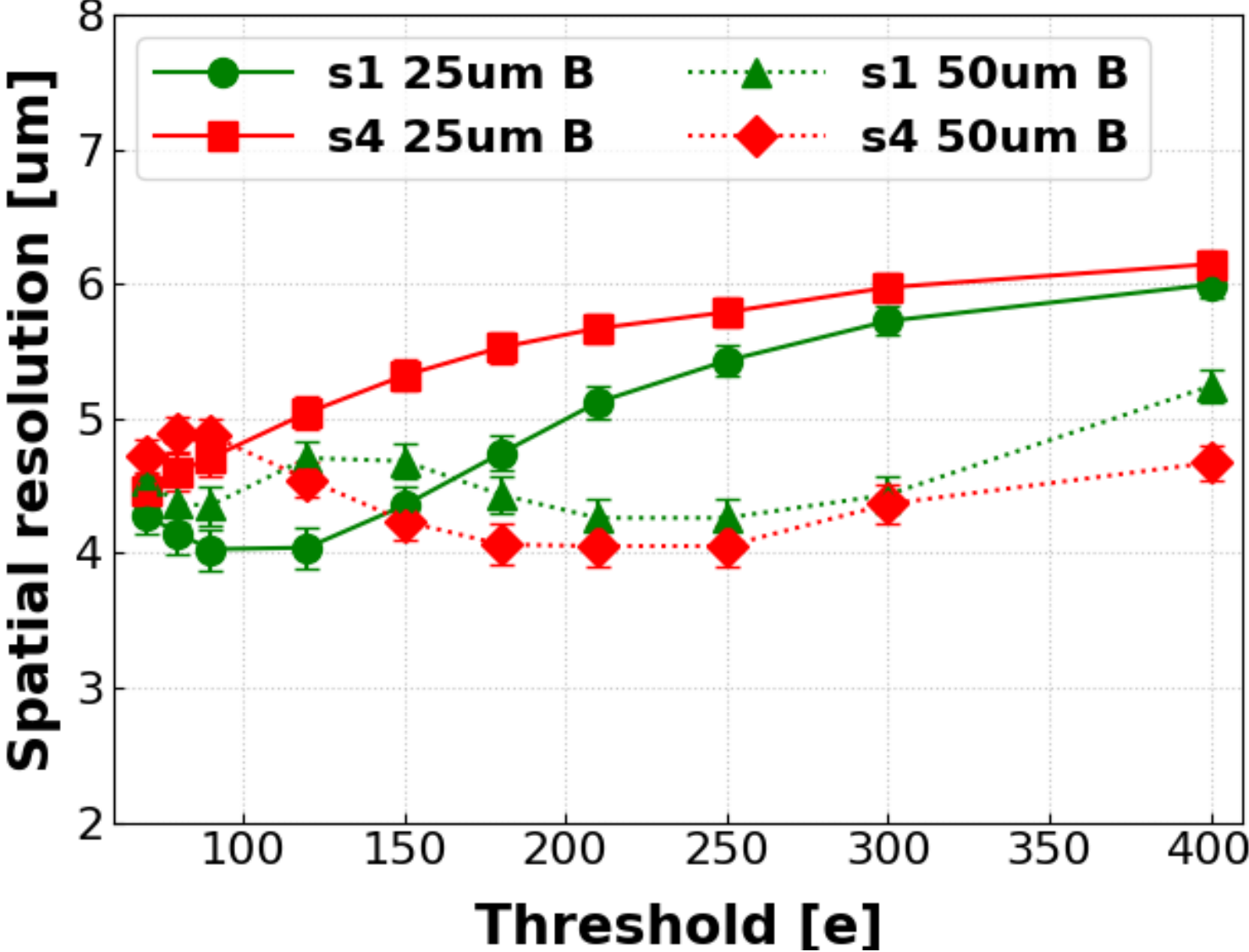
Before Irrad



After n Irrad



Before Irrad



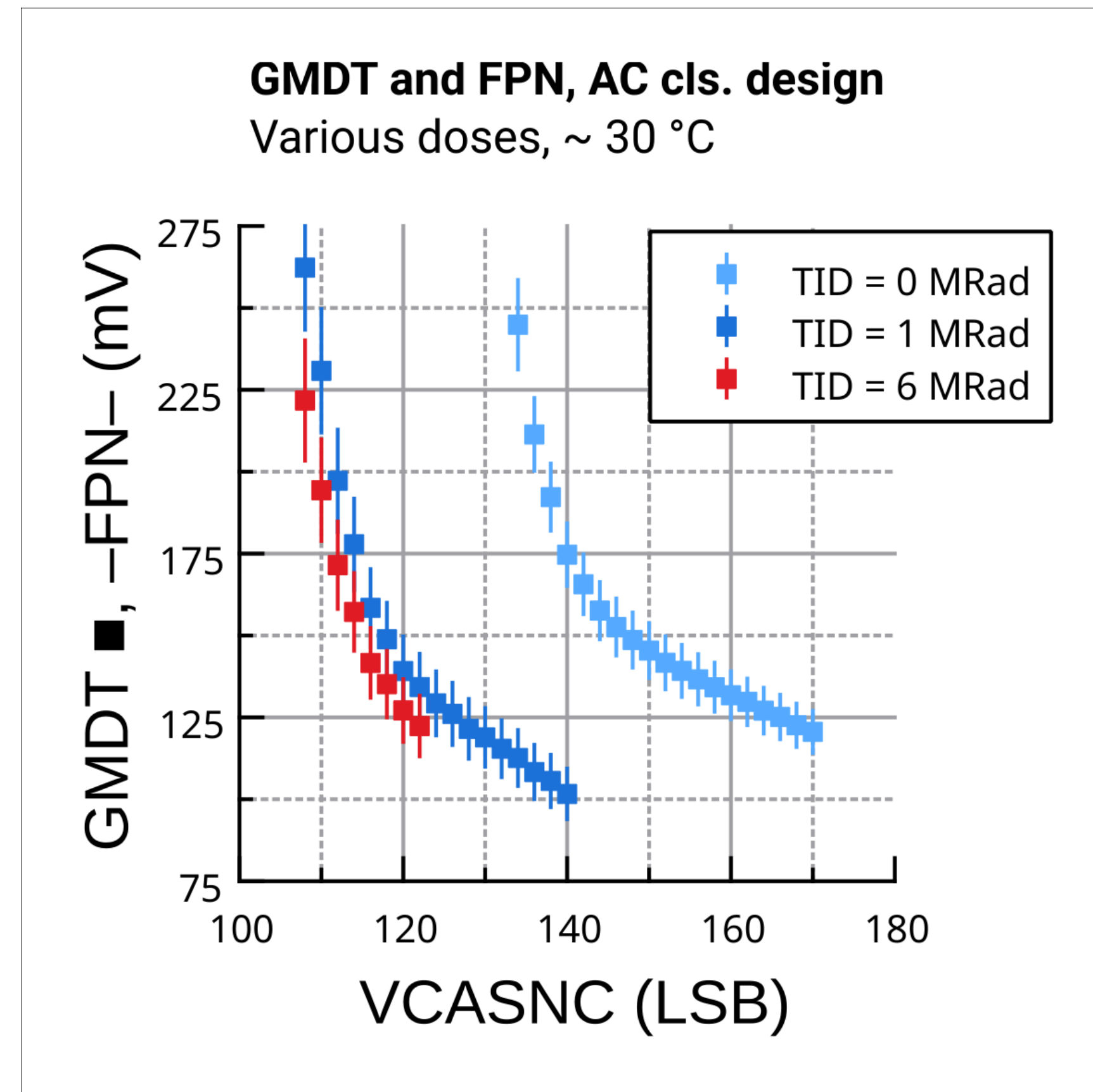
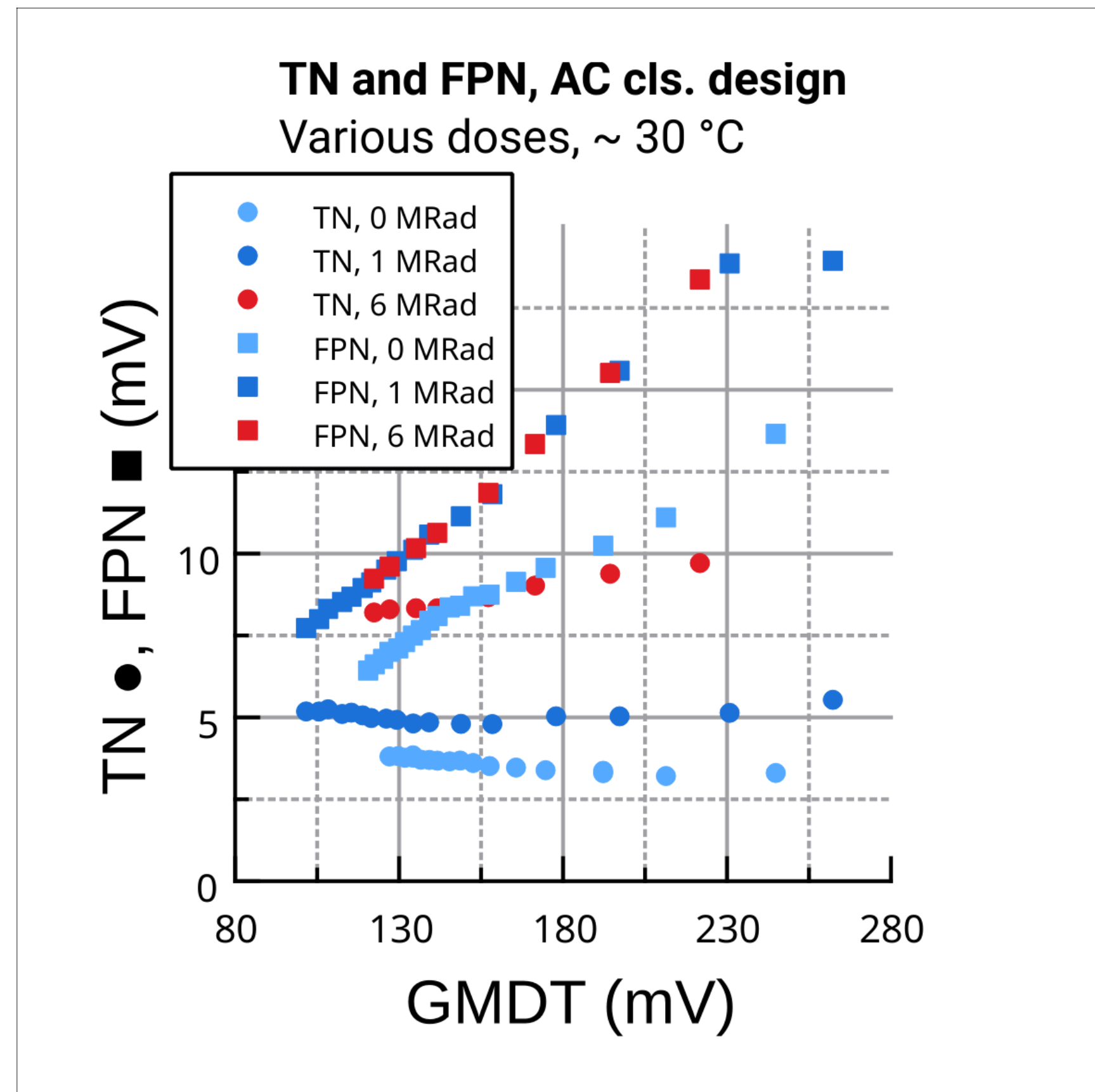


# Pre – Irradiation for a Homogeneous Response

Needs validation on wafer-level (in preparation, facility identified)

Difference: Powered-on state in MVD accelerates radiation effects

Fine-tuning of dose for unpowered wafers, exposure in wafer stack, ...





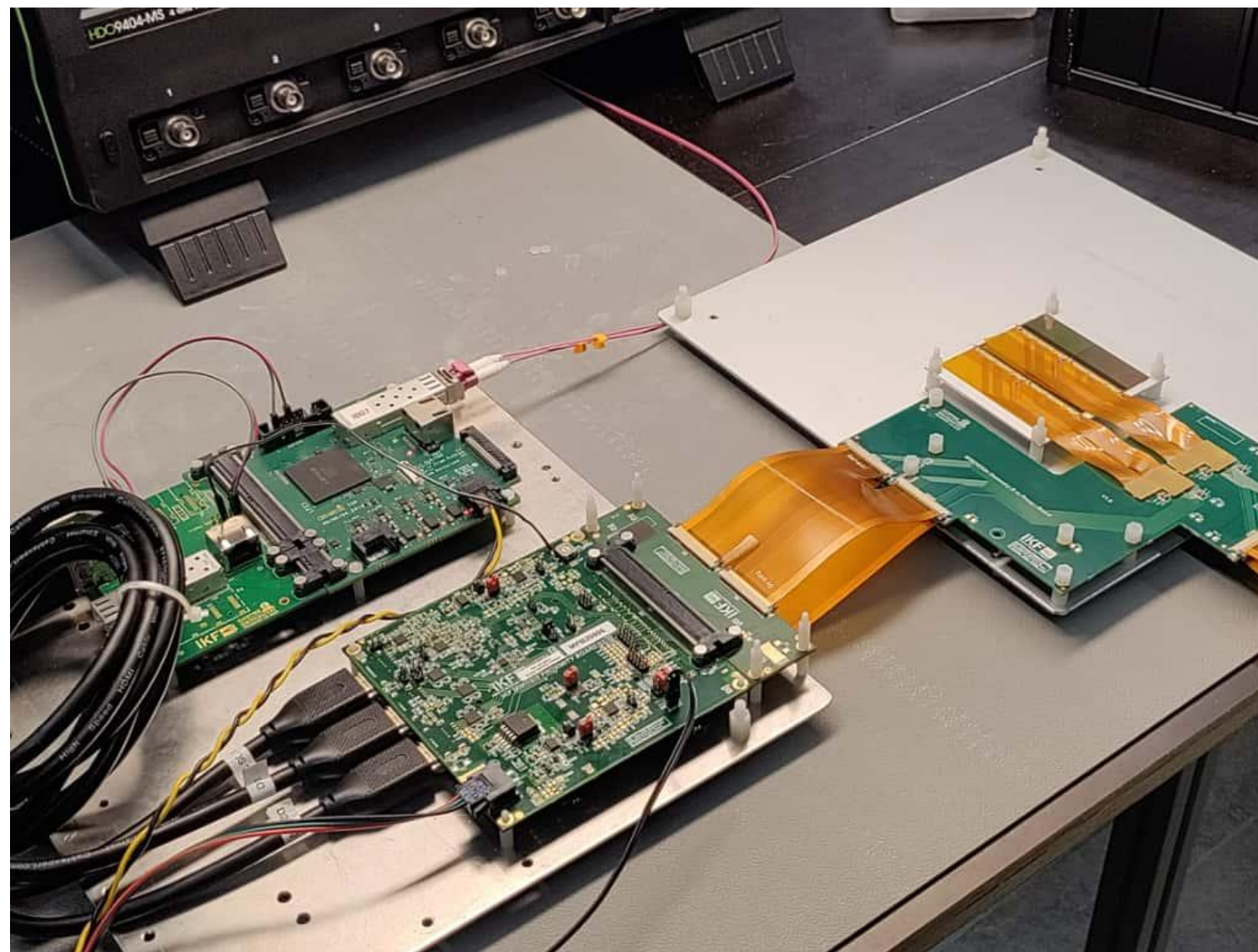
# MIMOSIS Readout Systems

## TRB-based (standalone)

MIMOSIS QA (lab, probe tests, integration, ...)

Easily configurable, flexible

→ Beam test prep, operation parameter studies, performance under realistic conditions, powering, signal integrity, ...



## CROB / CRI-based (CBM)

MVD in CBM, mMVD as proof-of-concept

Offset-heavy, not very flexible

→ optimizing CBM compatibility, data output & sorting, firmware development, ...



MVD/STS-ROB (pre-)produced

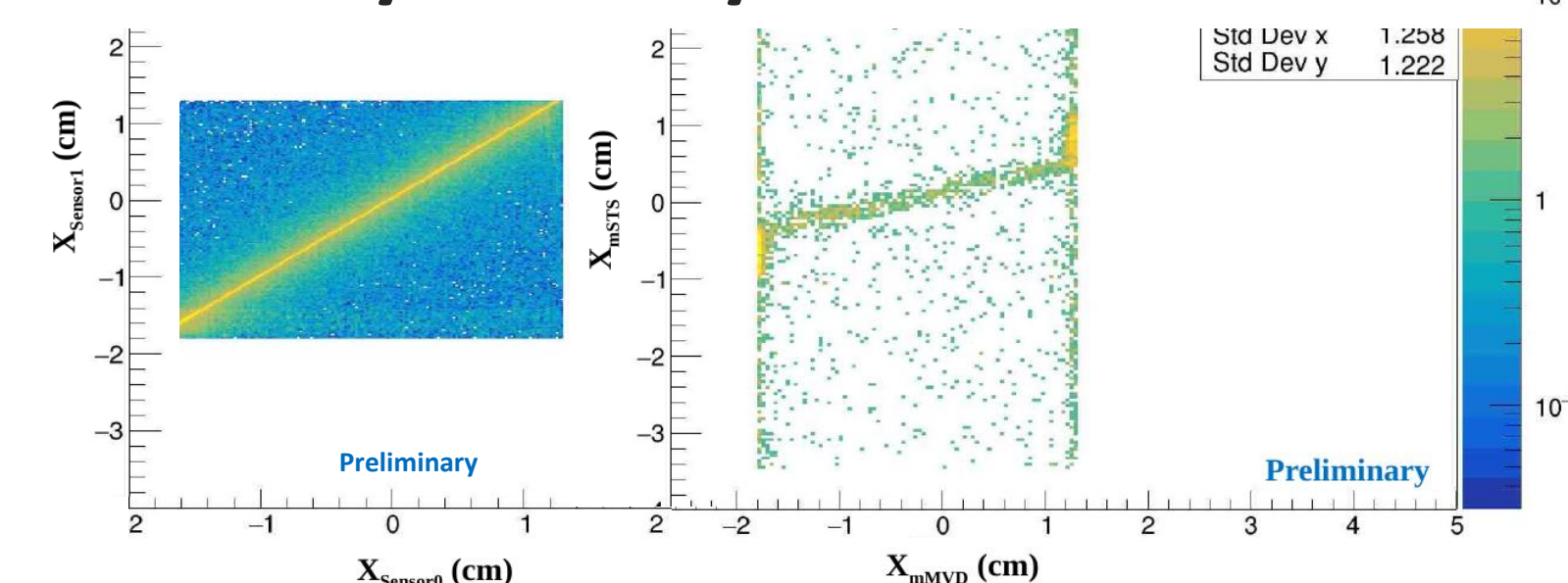
→ MVD electronics w/ know-how from both

→ CBM compatible

→ Add detector requirements (symmetries, radiation, space constraints, fail-safety, ...)

Jan Michel, Bene Gutsche, Ajit Kumar, Ben Meadows, FM

## mMVD/mMVD/mSTS correlation

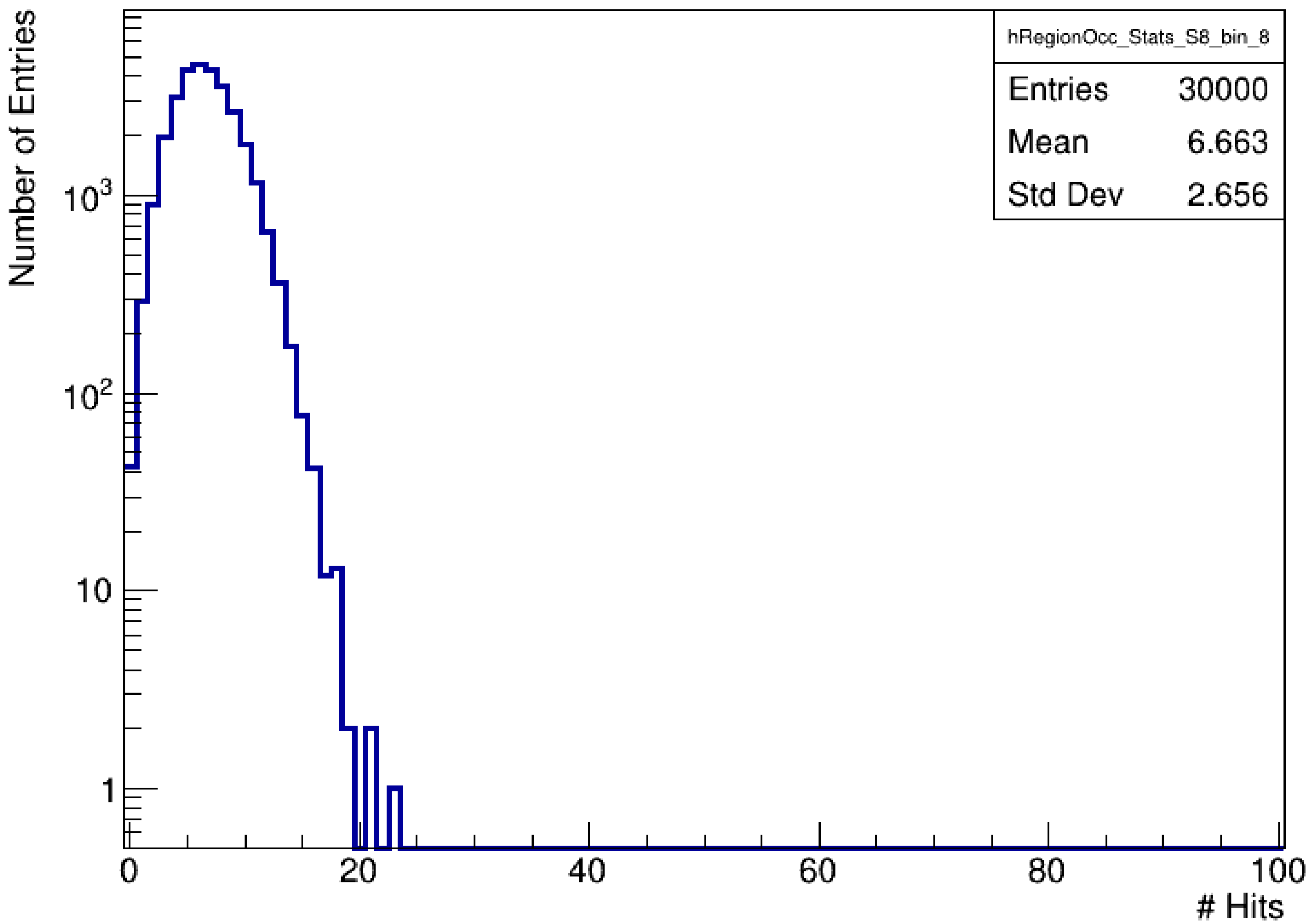




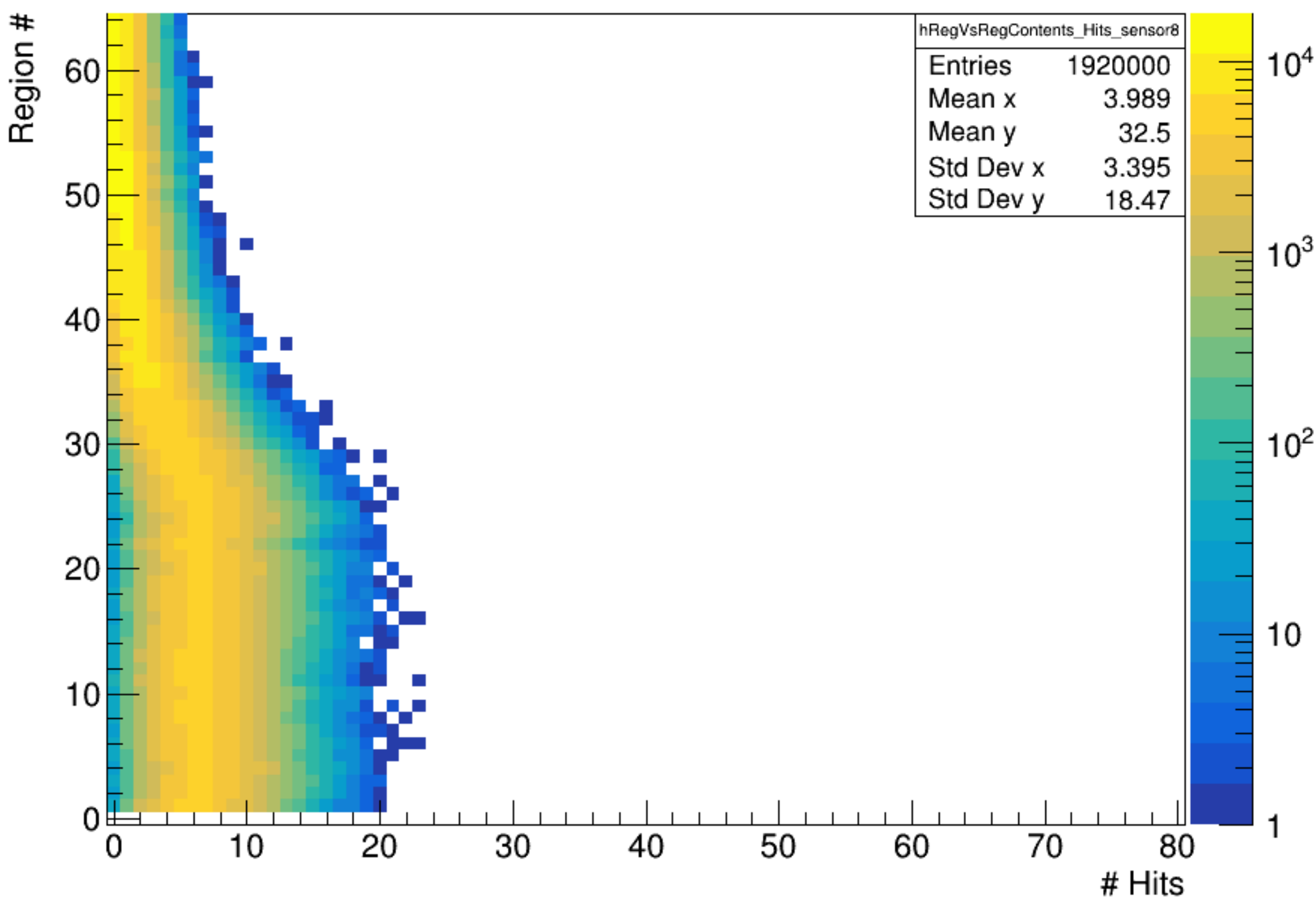
# Region Buffer Fill Levels

Region buffer fill levels, 100% field, geom 20c TR, 30 MHz beam Au+Au 12 AGeV,  
0.66% minimum bias interactions, 0.66% central interactions (incl. deltas)

Sensor 8: Region 8 Hits per Event



Region-wise Hits Sensor 8 (X)





# Reading out the MVD

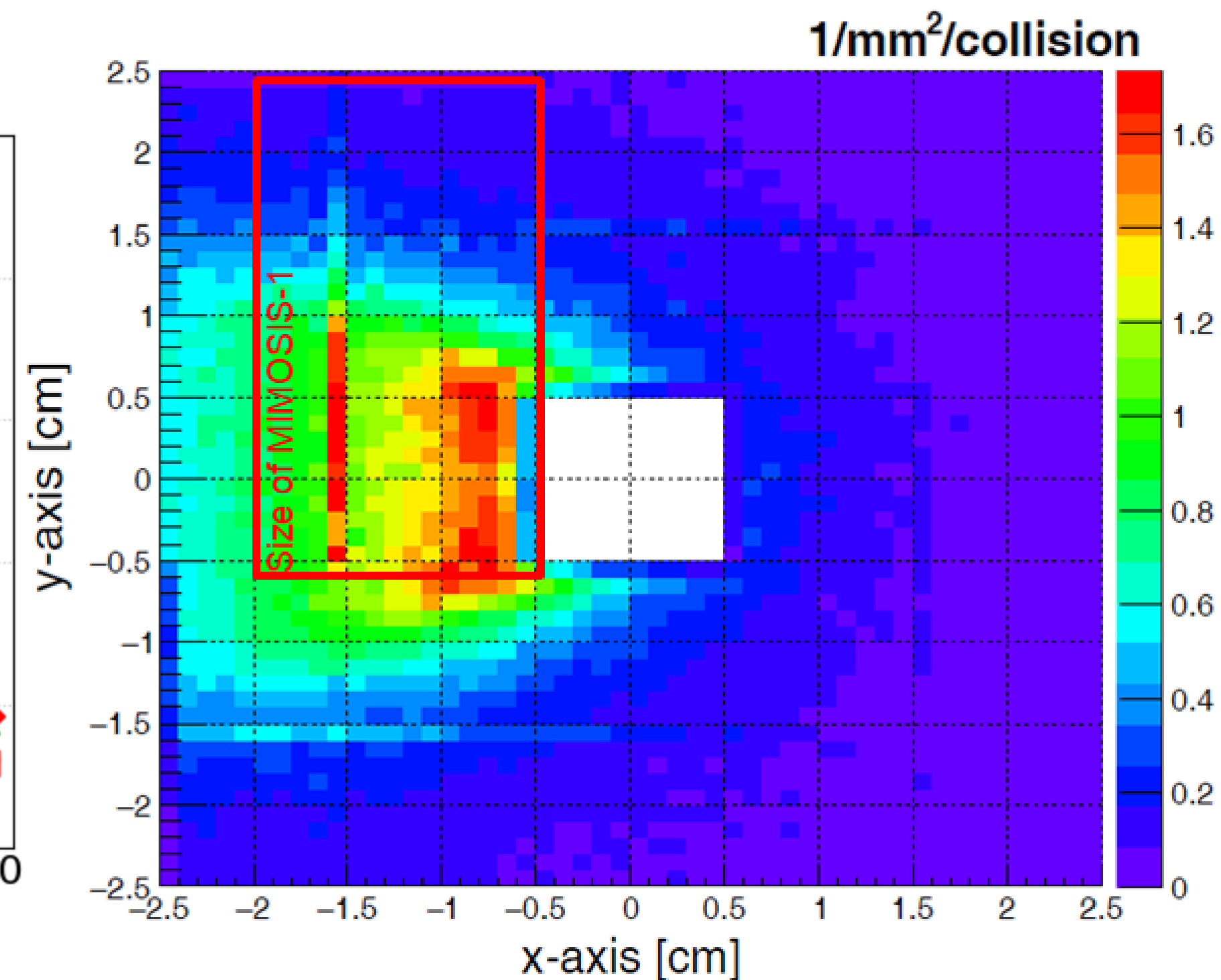
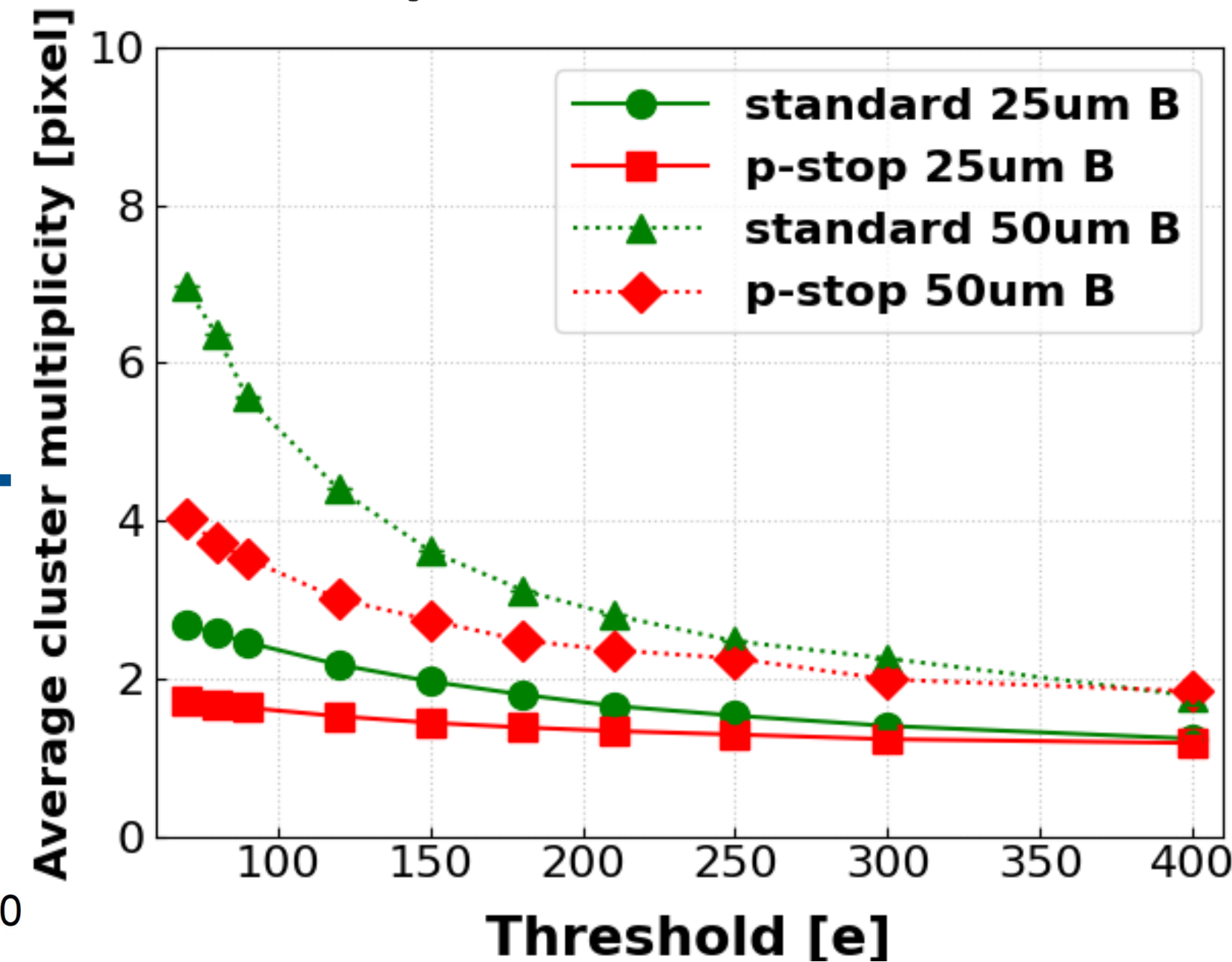
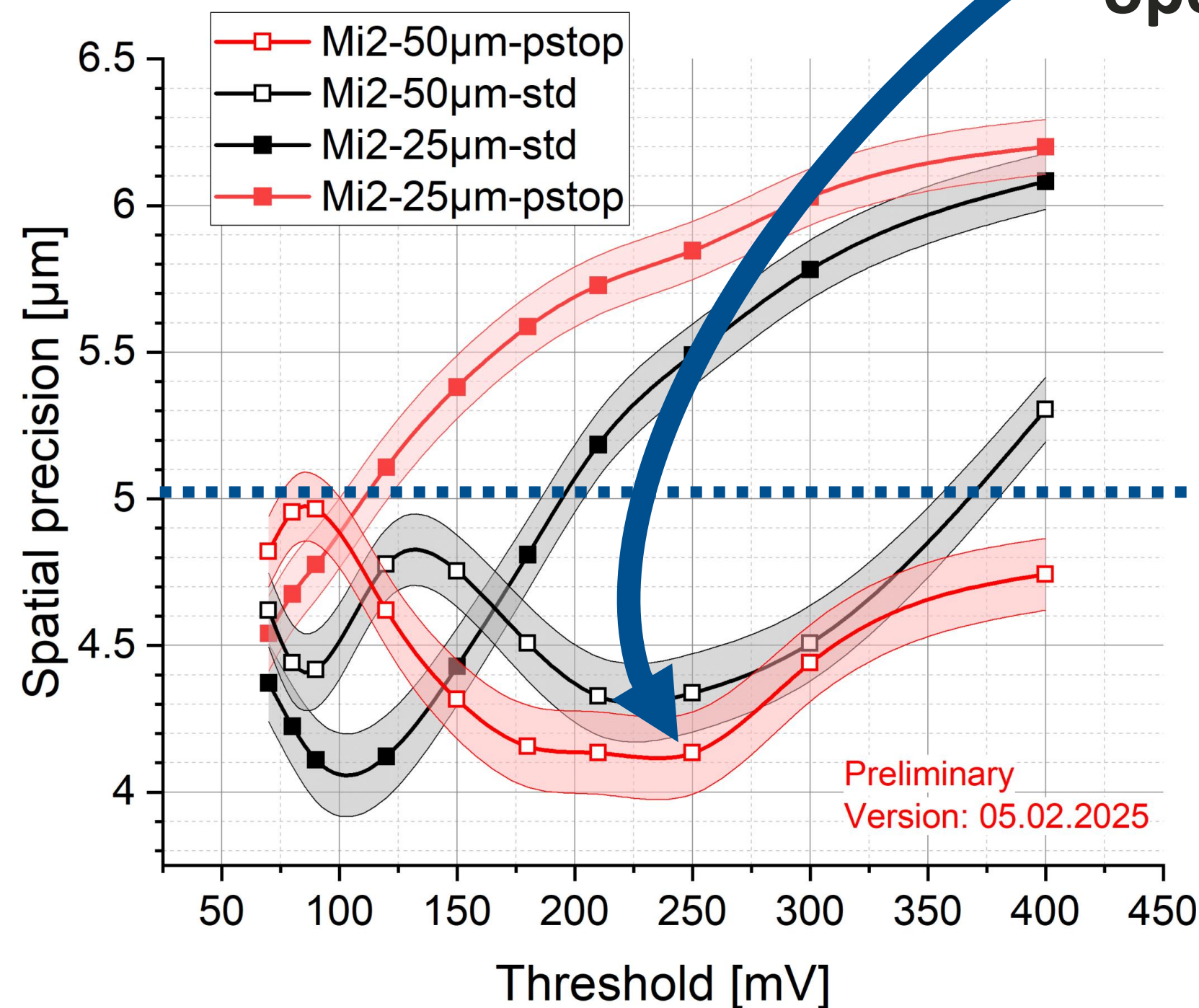
Sensor can run on 8, 4, 2, 1 320 Mbit/s data links

→ Optimize link layout of sensors w.r.t. interaction (data) rate, bandwidth usage, e-links (30 per CROB)

→ Hard constraints: physics, region buffer limitations (sensor), cluster sizes, space

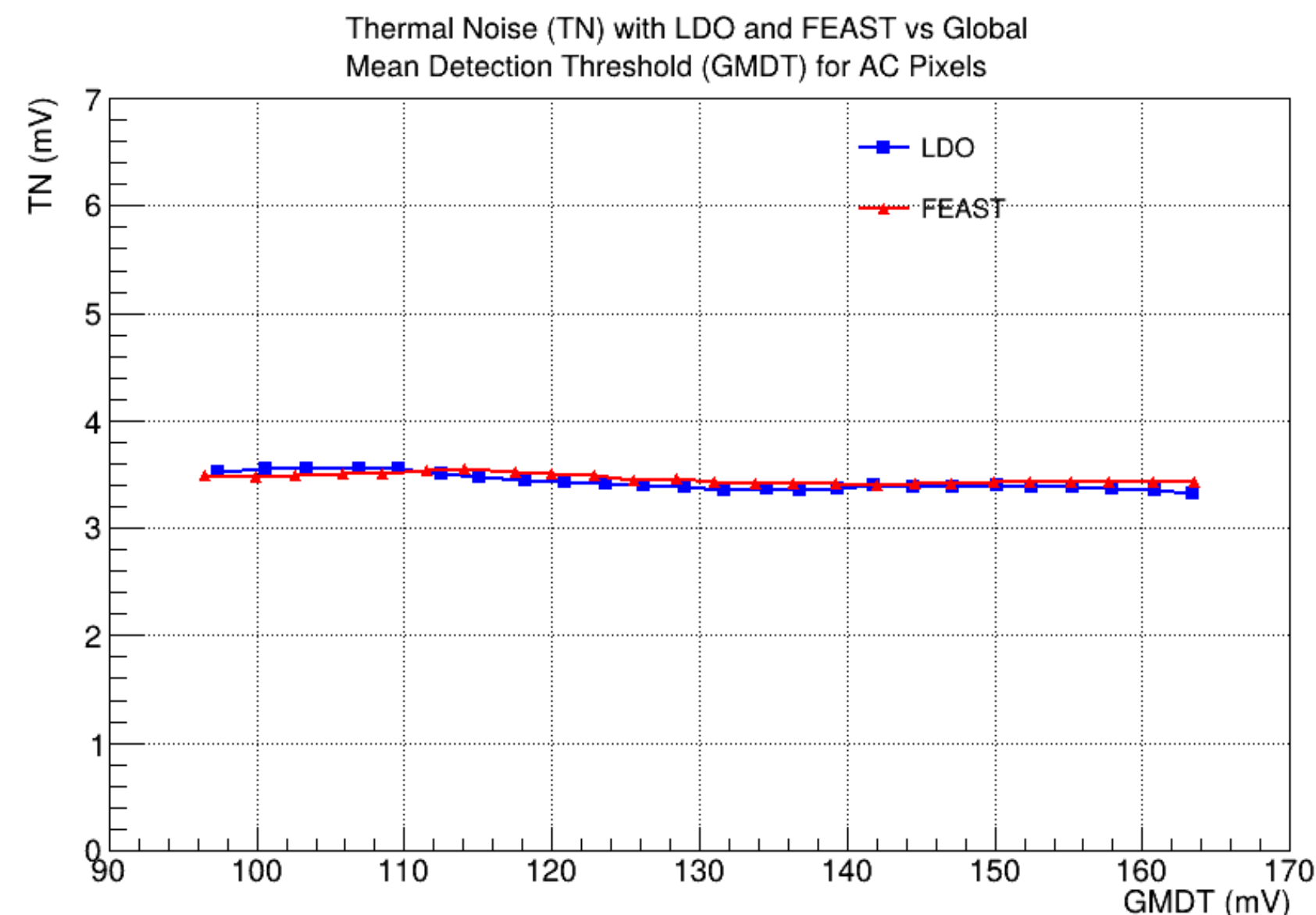
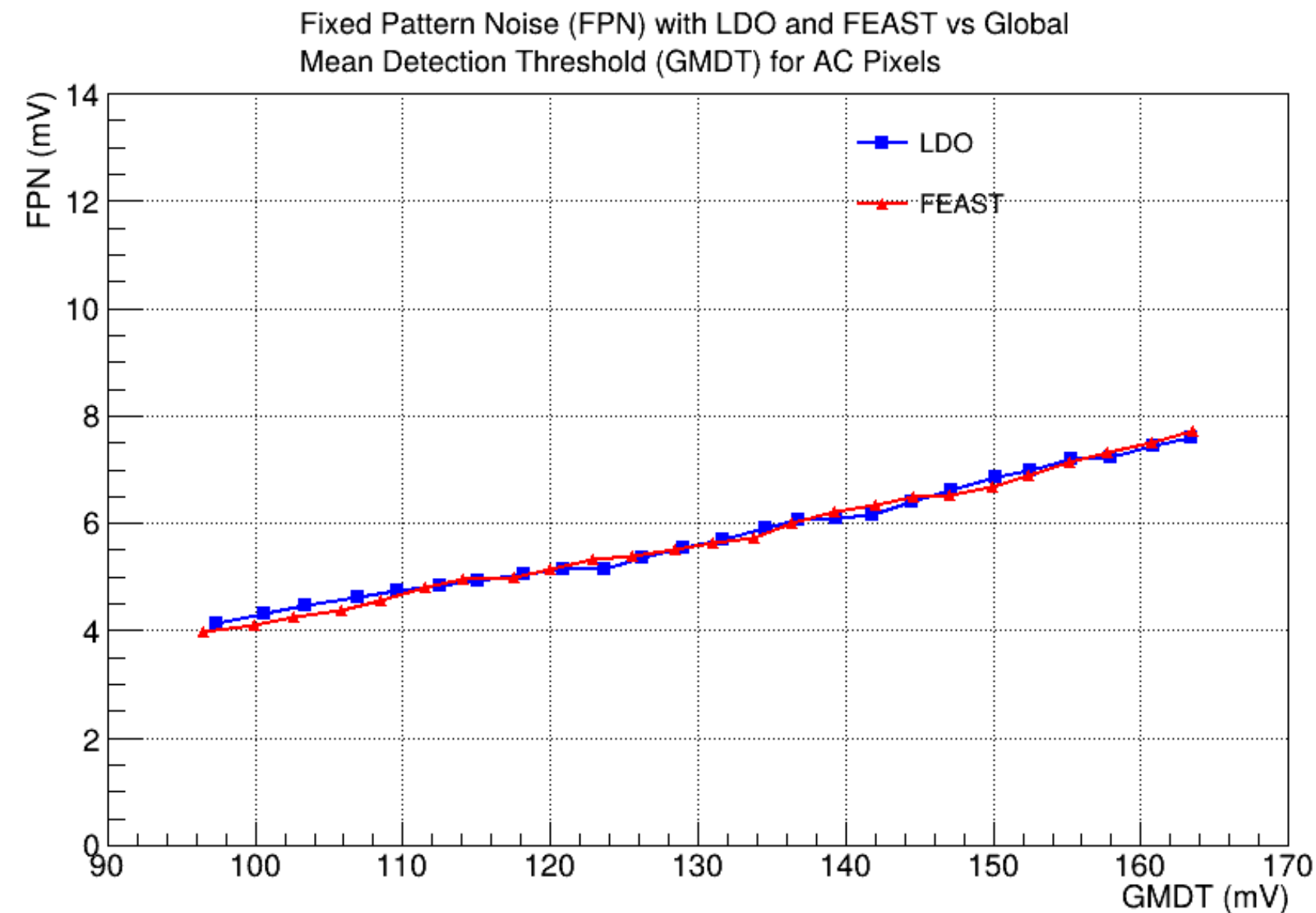
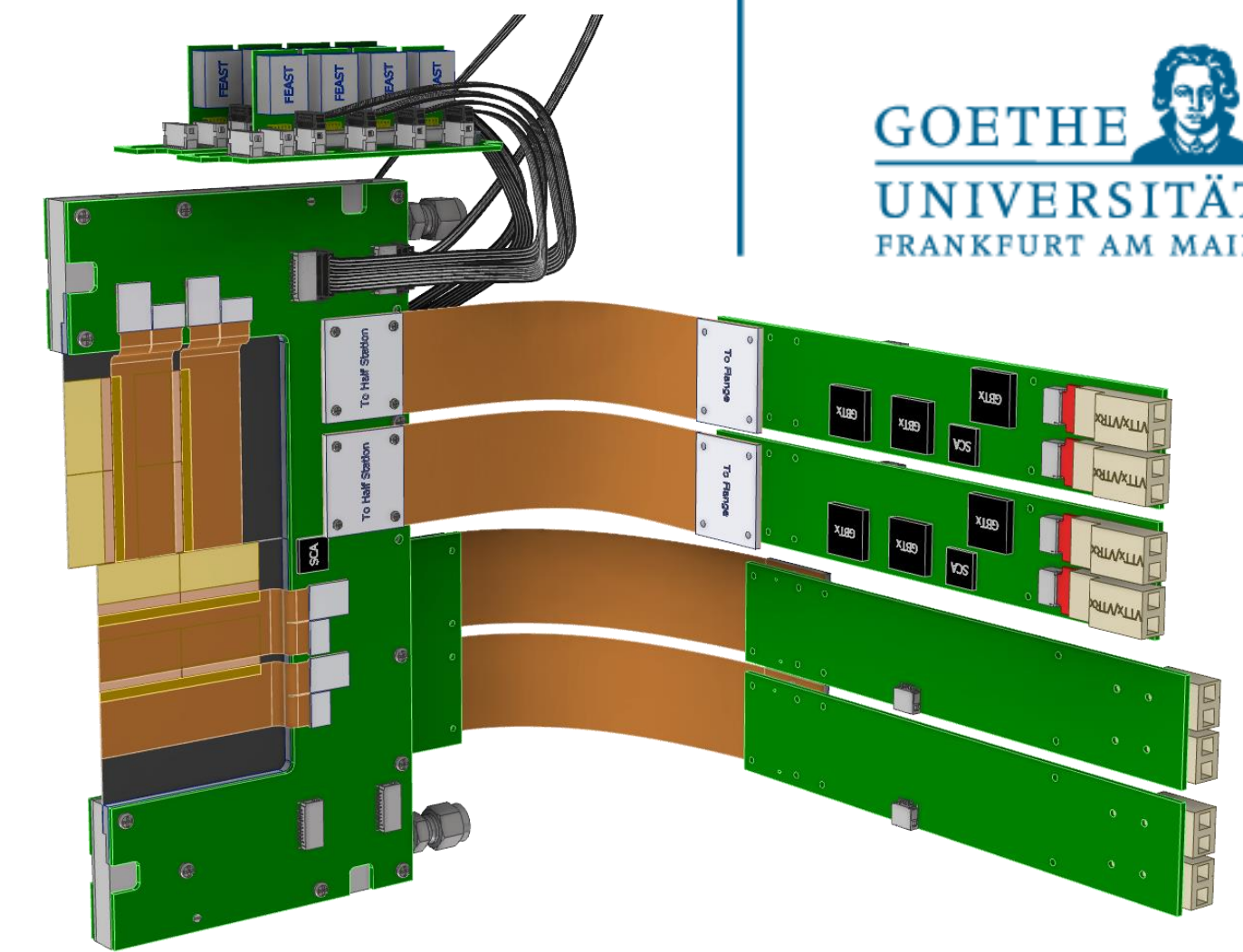
→ Soft constraints: acceptable data loss, safety margins, efficient use of resources, spatial precision

(Most likely) MIMOSIS-3 in  
operation, 2.5 pixels/MIP





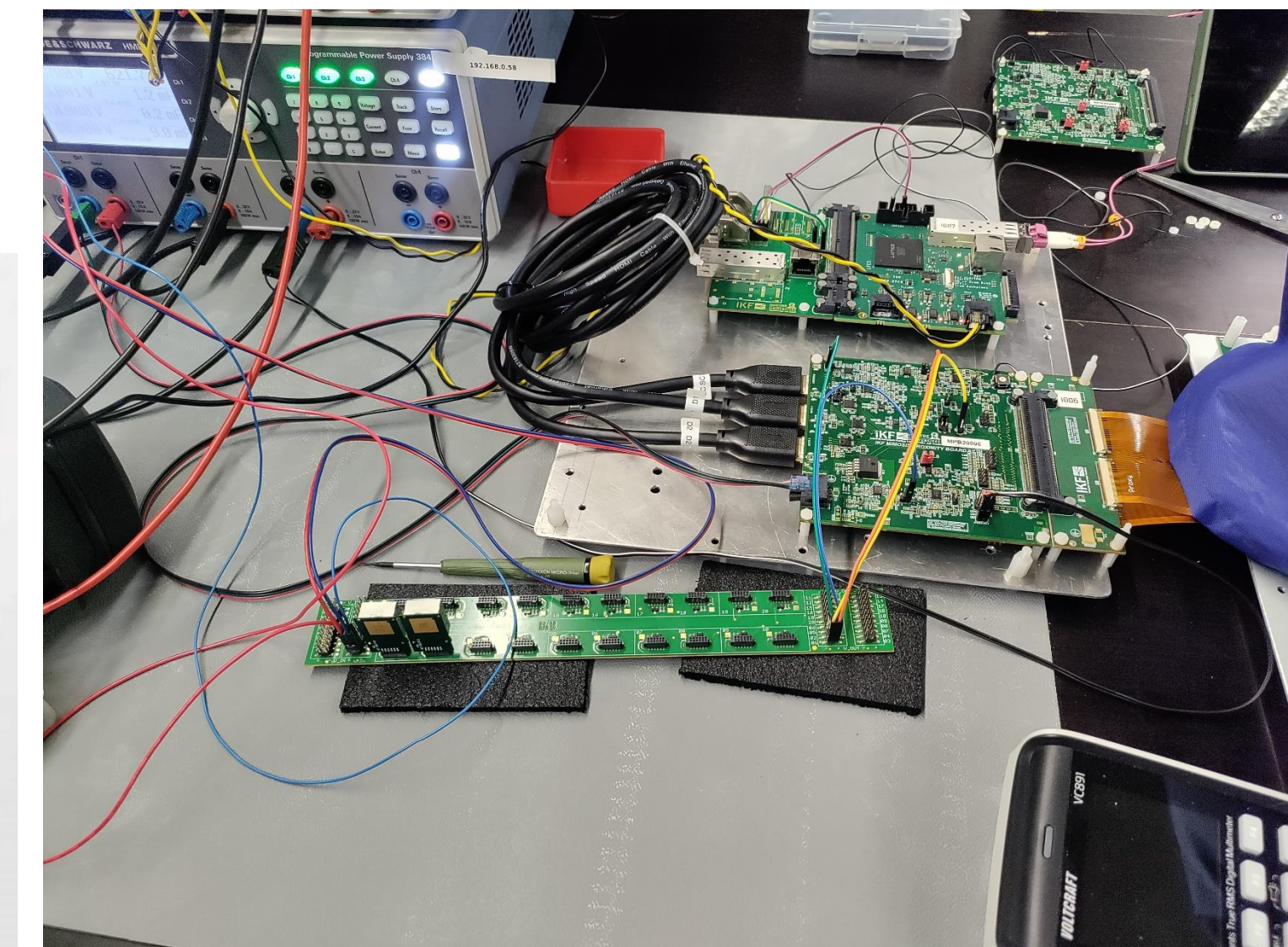
# Powering with FEASTs



Cross powering not observed  
Power supply failure scenarios tested  
→ VDD, VDA, HV uncritical  
→ Back bias is vulnerable  
→ Fail-safety tested, implemented on FEB

Ongoing: Occupancy fluctuation effects

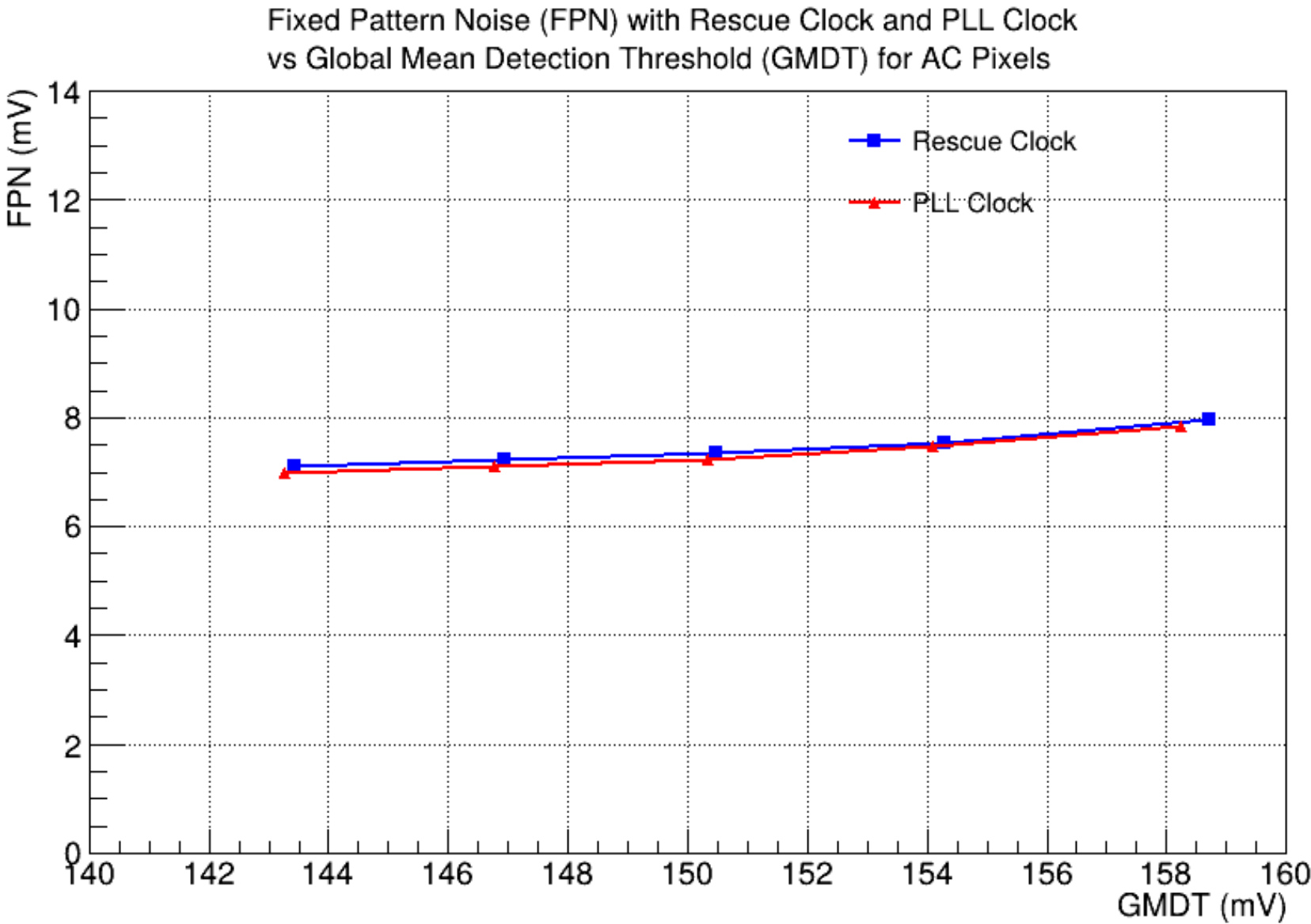
↑ Threshold Dispersion  
↓ Thermal Noise



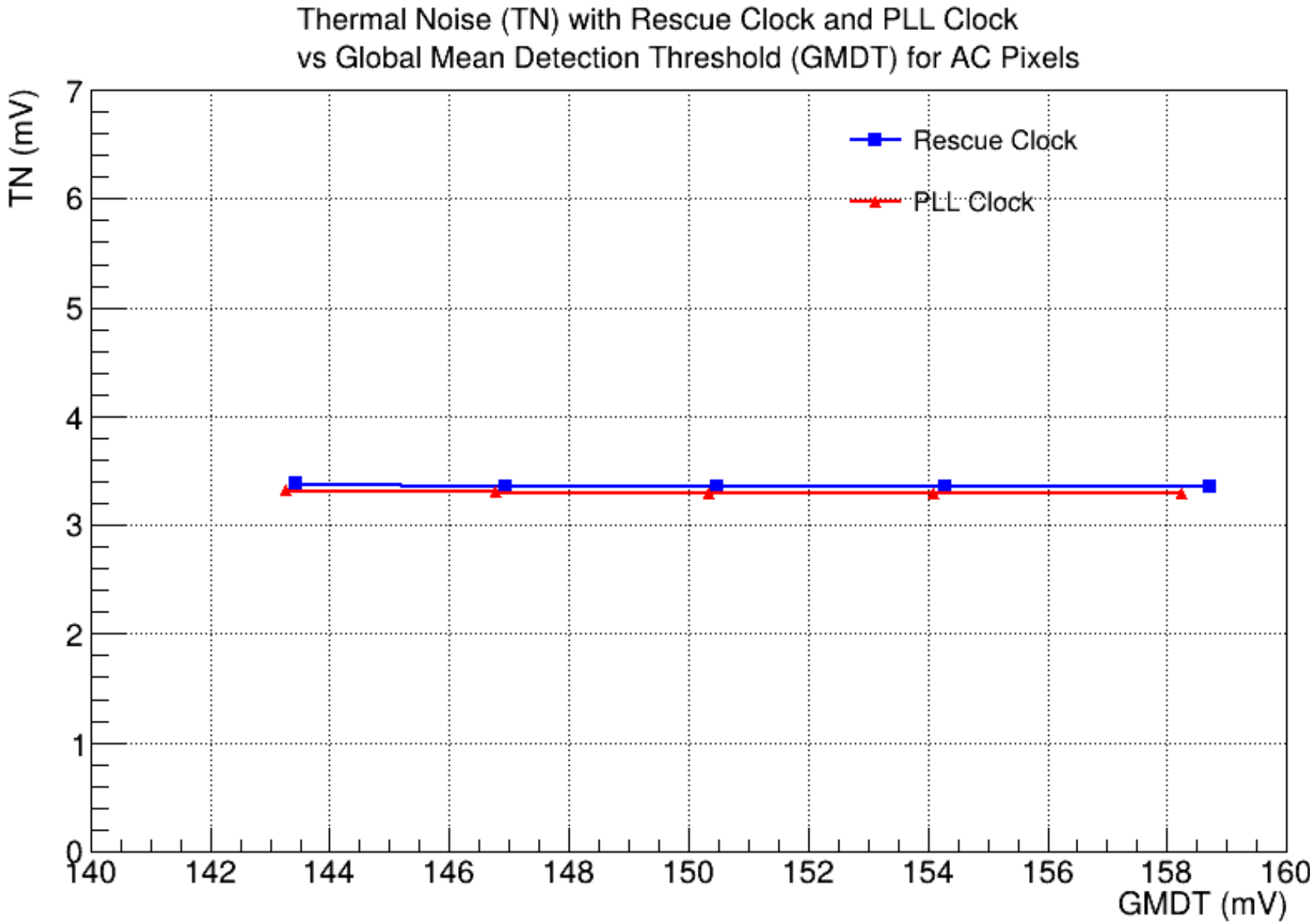
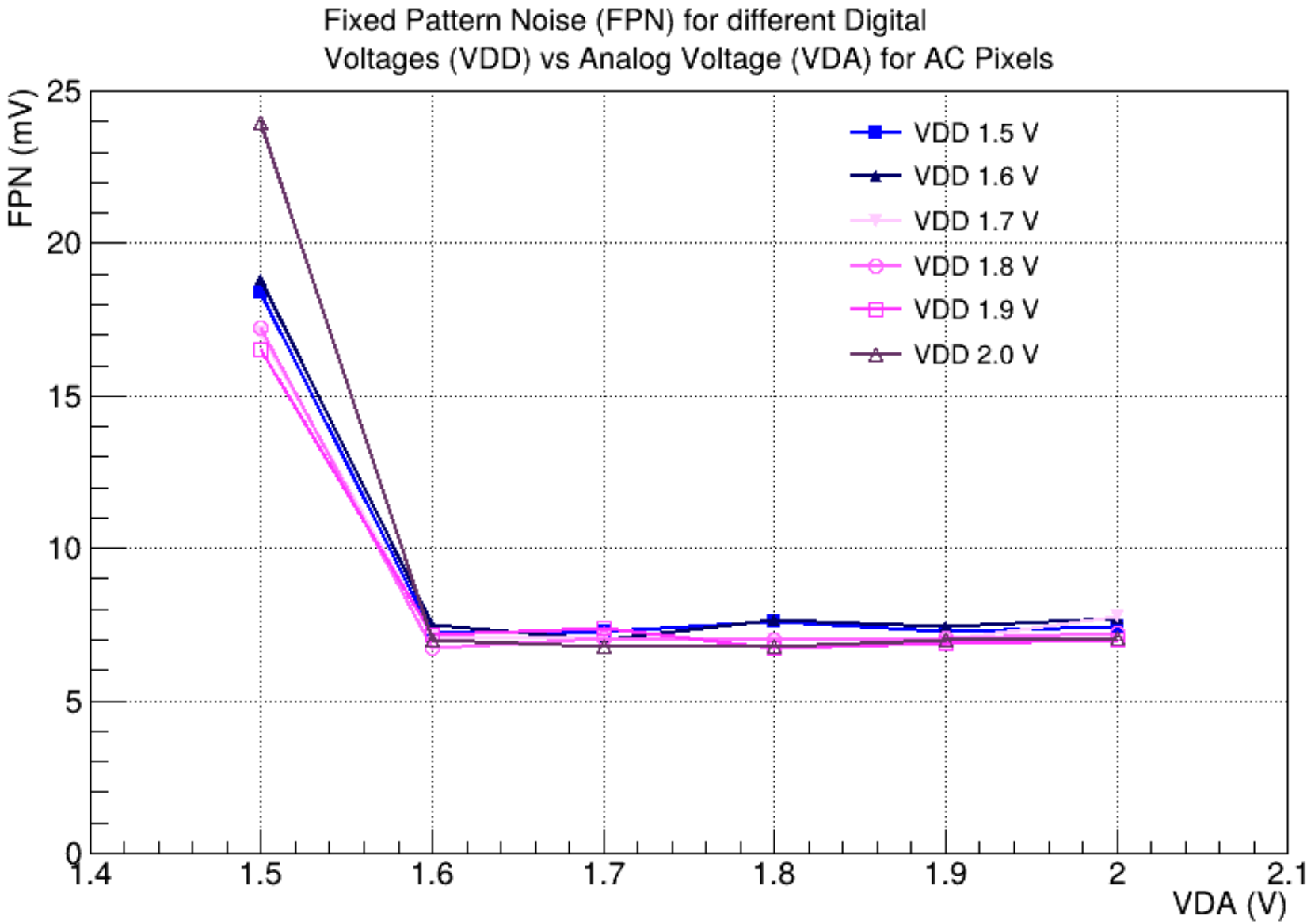
Jan Michel, FM



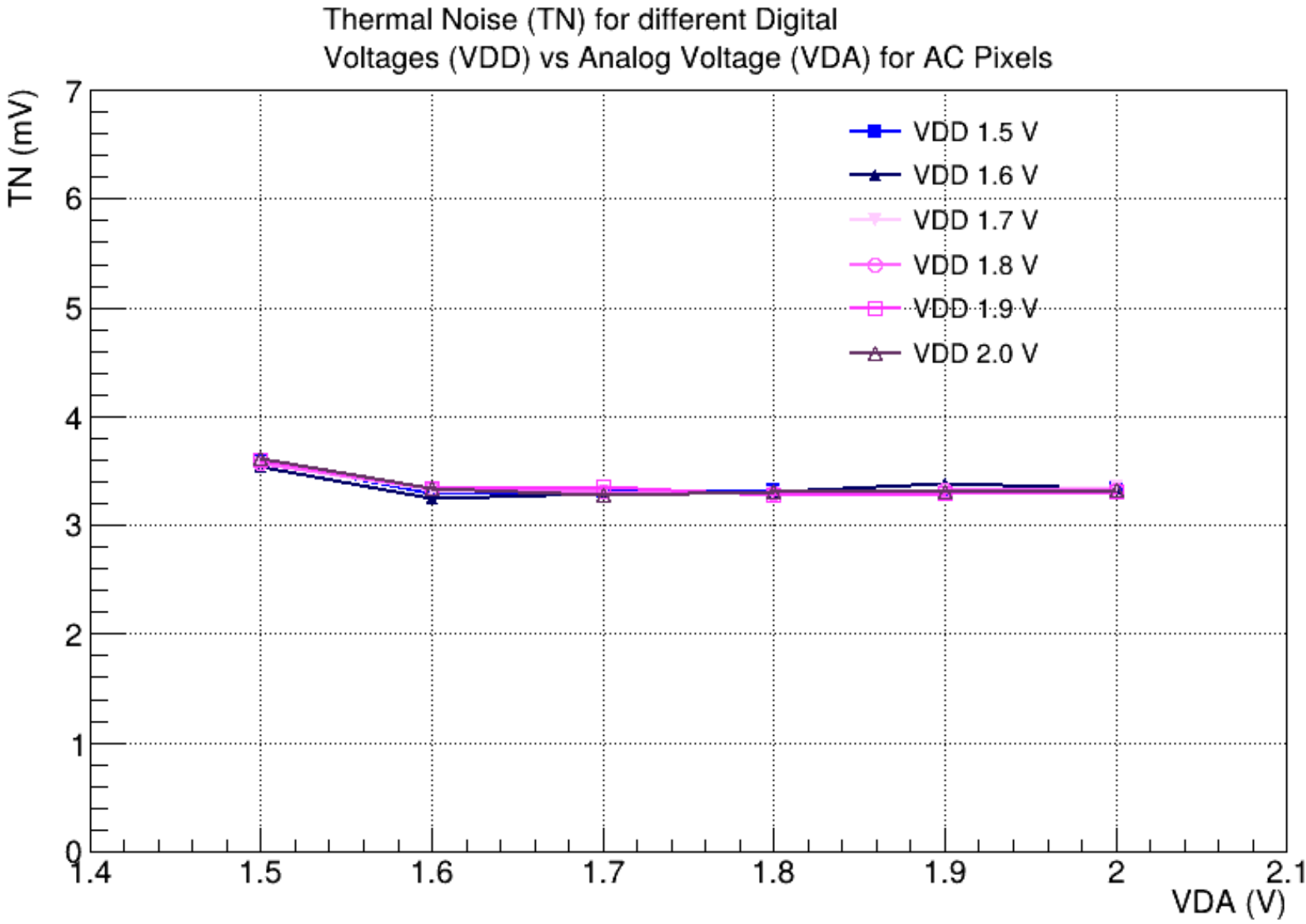
# Safe Operation Parameters



Threshold Dispersion  
← Internal/External Fast Clock  
Operation Voltages →



Thermal Noise  
← Internal/External Fast Clock  
Operation Voltages →



Jan Michel, FM



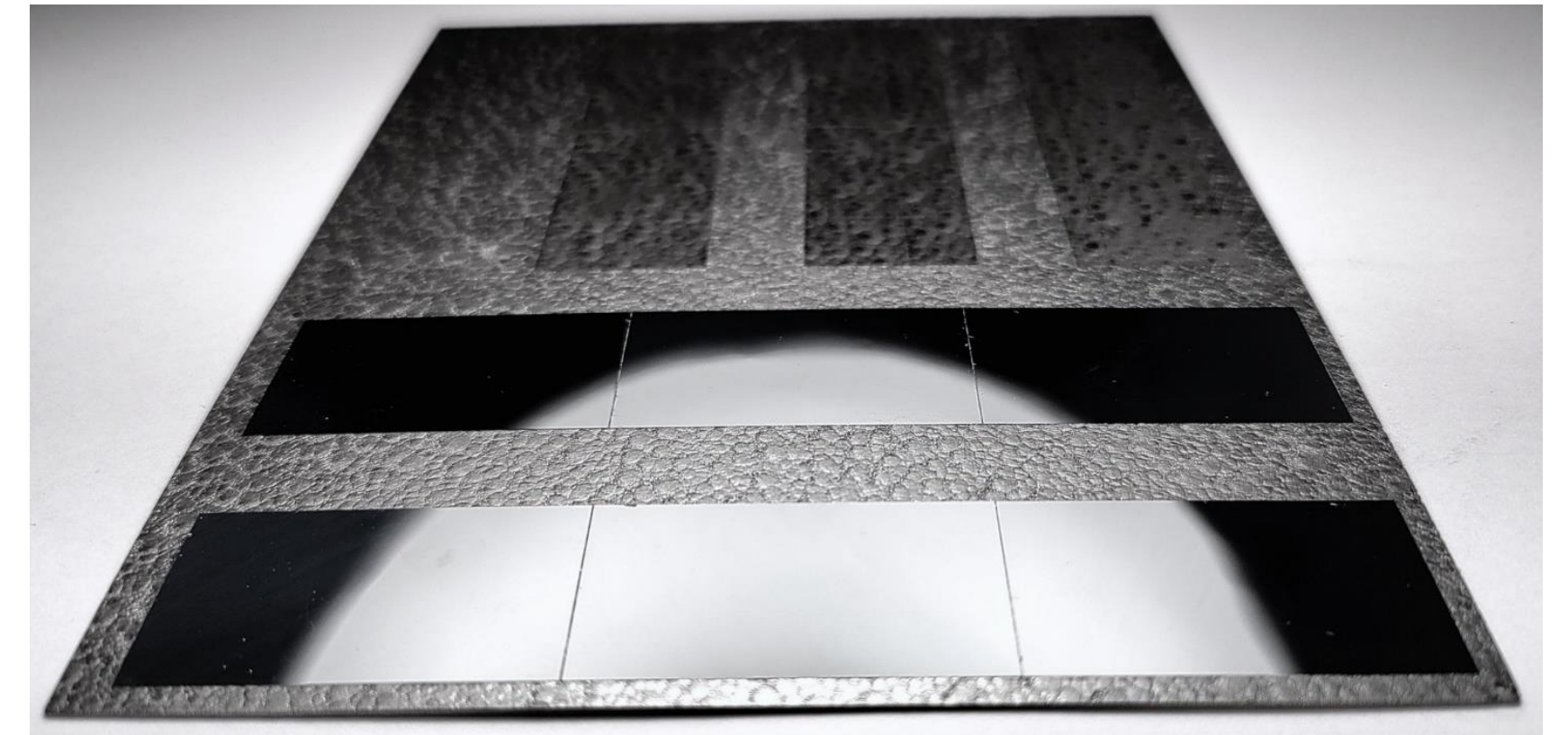
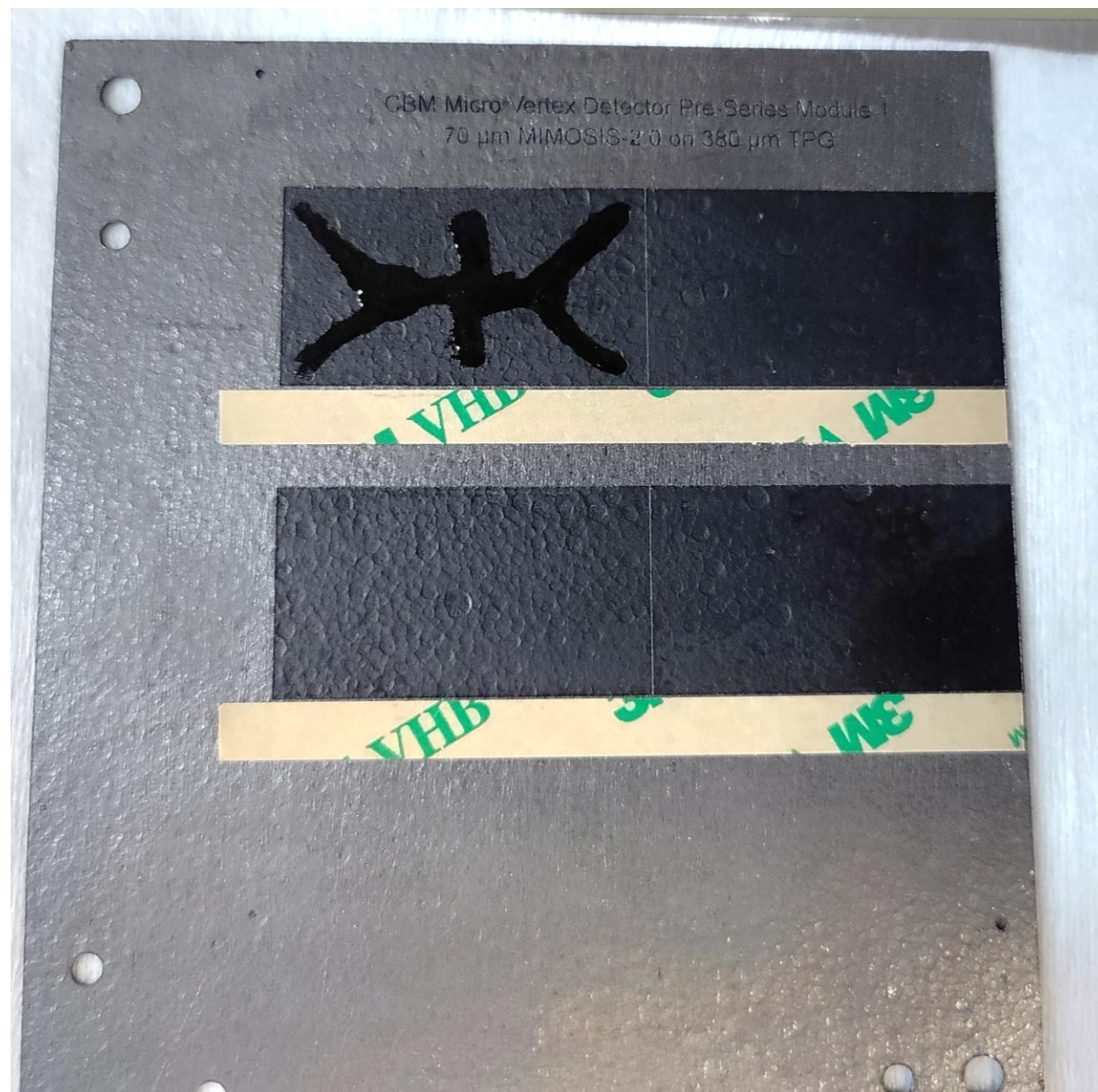
# Epoxy Gluing on TPG

CMOS MAPS directly on TPG

- Polished, 3D – structured, coated and activated sheets
- Epo-Tek 301-2 (FL also available, not tested by us)

Gluing optimized for vacuum operation

- No trapped air with minimal amount of glue
- Star pattern
- $3.7 \text{ mg/cm}^2$  ( $\sim 30 \text{ }\mu\text{m}$  of glue)



Optimized glue pattern on TPG

IR photography of Si dummies

Before – 2s

2min – cured

